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THIRD U.S. - JAPAN WORKSHOP

ON DIELECTRIC AND PIEZOELECTRIC CERAMICS

NOVEMBER 9-12, 1986 TOYAMA JAPAN

Prepared For: The Office of Naval Research

July 30, 1987



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INTRODUCTION

The Third U.S.-Japan Workshop on Dielectric and Piezoelectric Materials was held in Toyama, Japan, November 9-12, 1986. There were approximately 85 attendees, 25 from the U.S. and 60 from Japan. A large percentage (N 75) of the Japanese representatives were from industry, while industrial representation in the U.S. delegation was quite small (N 20%). The purpose of this series of workshops has been the fostering of an exchange of scientific information between individual researchers from the two countries. To this end, the Workshop was organized to provide as much time as possible for informal discussions.

Other than for two invited review presentations by Professor Eric Cross and Professor Noboru Ichinose, the papers consisted of a four minute summary and a poster presentation by each attendee. The attendees were asked to present the results of recent research rather than review material. Copies of the abstracts of each of the papers as well as the material presented in the posters are included in a later section of this report. In addition to the poster papers, four roundtable discussion sessions were held in paralled. These roundtable discussions were held in the areas of dielectrics, piezoelectrics, processing, and mechanical properties. Discussion leaders from the U.S. and Japan supplied topics and helped to guide the conversations. Finally, a meeting for/U.S. attendees only was held in Japan at the close of the Workshop to discuss what was learned regarding the important new areas of Japanese research and development as well as the industrial and economic aspects of these materials. In addition many of the U.S. attendees visited government, university, and industrial research laboratories, both before and after the formal portion of the Workshop. In some instances, these trips were arranged by the individual, but there were tour series set up by the Japanese, as well.

The value of this series of workshops on dielectric and piezoelectric materials to the United States is twofold:

First, the discussions, both formal and private, have provided a source of new research ideas for the individual scientist. In a number of instances, these ideas have evolved into new directions for research as well as collaborative programs with the Japanese.

Second, the collective knowledge gained by the U.S. attendees, individuals having many different areas of expertise, has aided the Navy in focussing on the newest and most important research directions which the Japanese are taking on these materials. It is clear that the components and devices based on these materials have played an ever increasing role in Naval applications as well as the U.S. technology as a whole. A summary of the newest areas of Japanese research and development on these dielectric and piezoelectric materials is presented in the next section of this report.

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SUGGESTIONS FOR FUTURE WORKSHOPS

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Based upon the successful exchange of information in the previous three Workshops, we have made preliminary plans to hold a fourth meeting in the United States in the Fall of 1988. The tentative arrangement is that this Workshop would be held at the National Bureau of Standards in Gaithersburg, MD. We do have a number of suggested changes in the format of the meeting, which we believe will increase its value to both the Navy as well as U.S. industry:

- 1. The post-Workshop meeting for the U.S. attendees should be lengthened considerably, perhaps to as much as half a day. This meeting provides a way to obtain a collective view of Japanese R&D from the perspectives of industrial, university, and government researchers. We should take this opportunity to help form an overall picture of where the Japanese are going in terms of their developments in dielectric and piezoelectric ceramics.
- 2. In connection with the above, we should make a much stronger attempt to encourage U.S. industrial representatives to attend, and contribute to this Workshop.
- 3. One way of obtaining more industrial participation may be to eliminate the formal plant visits which have been associated with this Workshop in the past. These plant visits, however, can be important sources of information. Thus, it is suggested that such visits be arranged on an individual basis.
- 4. Any roundtable discussion sessions should be more highly structured. Individuals from both countries should be asked to prepare advanced lists of specific topics and questions.

We believe that these modifications should help improve the Workshop, and help provide an even greater exchange of information.

DIELECTRIC AND PIEZOELECTRIC CERAMICS: A PERSPECTIVE ON RESEARCH AND DEVELOPMENT IN JAPAN

Stephen W. Freiman

National Bureau of Standards Gaithersburg, MD 20899

and

Robert C. Pohanka

Office of Naval Research Arlington, VA 22217

BACKGROUND

This summary represents the observations and opinions of a number of material scientists regarding the current status and most exciting topics in Japanese research and development on dielectric and piezoelectric ceramics. These scientists include many of the U.S. attendees at the Third U.S.-Japan Workshop on Dielectric and Piezoelectric Materials held November 9-12, 1986, in Toyama, Japan. The Workshop itself consisted of poster presentations by each of the U.S. and Japanese participants as well as four roundtable discussion sessions. Also, many of the U.S. attendees visited Japanese industrial and university laboratories both before and after the Workshop.

The report is divided into two sections, the first describing work on dielectric ceramics, followed by a section on piezoelectric materials. A number of application areas for each class of material are discussed.

DIELECTRICS

The primary application and certainly the current major market for ceramics as dielectric materials is in multilayer capacitors. The focus of much of the current attention of the Japanese is on capacitors containing lower cost electrodes. Two types of electrode systems are being considered. In the first, capacitor compositions are chosen in which Ag:Pd electrodes containing a large Ag/Pd ratio can be used. Lowering the Pd content in the electrode reduces the cost of the capacitor, but also reduces the temperature at which the capacitor must be fired in order to prevent electrode degradation. These "low fire" compositions are widely used in Japan. The second approach involves the use of Ni electrodes. The stability of the Ni electrodes is directly related to the partial pressure of oxygen in the firing atmosphere. These capacitors are doped with Ca to achieve the correct stoichiometry in the ceramic, which permits them to be fired in a low oxygen partial pressure. The Japanese advances in this area would seem to have occurred primarily through an experimental approach. However, the Japanese have made good use of fundamental research carried out in the U.S., Europe, and elsewhere. For instance, the understanding of the role of the Ca in base metal, i.e. Ni, electrode compositions was

based, in part, on the work of Professor Don Smyth at Lehigh University.

Another area of Japanese activity in multilayer capacitors observed during plant visits to TDK Corporation was the screen printing of dielectrics. Screen printing allows the formation of very thin layers of ceramic, giving rise to better homogeneity and reducing the tendency to bowing in thick specimens with a large number of layers. The improved homogeneity results in high capacitor reliability. Mitsubishi Mining and Cement Corporation has commercialized this process.

The Japanese are also interested in the use of relaxor compositions for multilayer capacitors in order to obtain materials with a high dielectric constant, low firing temperature and compatibility to electronic packaging materials. They reported on the properties of lead zinc niobate and suggested that this material is a promising candidate for capacitor applications. A major producer of relaxor materials is NEC Corporation, who can put capacitors directly on substrates. development of these kinds of components involves understanding the mechanical compatibility of the capacitors and substrates, as well as the processing behavior of materials having different chemical compositions and physical properties. Finally, private discussions with individuals from Murata suggest that there may be serious cracking problems in ceramic capacitors made from relaxor compositions. It is not completely clear at present whether these problems arise because of an intrinsic weakness in the relaxor materials or are due to other causes such as processing defects.

The use of Pb injected electrodes in multilayer capacitors was briefly discussed. While there are some advantages to this system, the Japanese and U.S. representatives agreed that their use is not practical.

There did not appear to be a great deal of effort in Japan on determining the mechanical properties of capacitors. The one paper in this area was presented by Mr. Kishimoto Koumoto and Professor Yanagida from The University of Tokyo. Based on the similarity in Weibull distributions, these investigators concluded that a direct correlation exists between fracture strength and dielectric strength in fine grain size barium titanate. The correlation for larger grain size material was not as good.

In a related area, it was reported that TDK has developed a thermal shock testing technique which can be used to detect delaminations in capacitors.

The other major application for dielectric ceramics is in products used at microwave frequencies, e.g. tuned waveguides used in cellular telephones and satellite television communication systems. These waveguides are tuned to specific frequencies by varying the permittivity and dimensions of the dielectric resonator. There were four papers on microwave applications presented by Japanese companies at the Workshop. It was pointed out that the critical parameters for optimum performance are a relatively high dielectric constant at microwave frequencies, a very high Q for signal discrimination

and to reduce power losses. A zero or negative temperature coefficient of the resonant frequency is also required. Most of the Japanese work appears to be quite empirical; compositions are varied and properties determined. The work reported by Murata was less empirical. In their work, the dielectric loss was matched with the infrared spectra of the materials. They considered changes in properties based on order/disorder in the structure. In the case of the work reported by Narumi China Corp., the microwave properties were altered by changes in the crystalline phases in the material. The "optimum" properties reported by Narumi China were $\epsilon'=38$ and Q=9000 at 4GHz, and $T_c=2ppm/^{\circ}C$. It is also apparent that the U.S. is doing virtually nothing in the microwave ceramics area.

PIEZOELECTRICS/ELECTROSTRICTIVES

One of the important research topics on piezoelectric materials is in the area of ceramic/polymer composites. Applications for this relatively new class of materials include improved sensitivity transducers for medical applications, which have a better impedance match to human tissue, as well as improved loudspeakers. One way of creating a piezoelectric composite with a controlled impedance is to produce a material having a gradient in filler concentration. There are approximately five Japanese companies involved in piezoelectric composite development. They do not seem too concerned with new materials but are concentrating on producing known compositions. They appear to be behind the U.S. in the theory of piezoelectric composites, but are neck and neck on the practical aspects of the industrial development of these materials.

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One of the exciting new areas in which the Japanese are well ahead of the U.S. is in the development of practical piezoelectric and electrostrictive actuators and motors. These devices are based on materials such as PZT and lead magnesium niobate. In general, these applications are best formulated from hard piezoelectric materials having low hysteresis, low aging, and a high fracture toughness. A high Q increases the potential efficiency of the motor. Since one wants the largest possible strains in the material for a given applied voltage, piezoelectric compositions near morphotropic phase boundaries appear to be the most attractive.

There were six papers on motors and actuators presented by the Japanese at the Workshop. Professor Kenji Uchino at Sofia University continues to be an innovator in this field. His review paper on these devices, published in the Proceedings of the Sixth IEEE International Symposium on Applications of Ferroelectrics (1986), is particularly informative with regard to potential applications and material property requirements. Professor Uchino has recently become concerned with the mechanical reliability of the materials involved in these motors, and has been doing work on the fracture of PLZT, which is a good electrostrictive material. He has observed that the critical fracture toughness increases as the grain size decreases for three different lanthanum concentrations. Matsushita and Tovo

Soda (among others) are apparently developing a whole family of small, low speed, high torque, piezoelectric motors. These motors can be made cheaply. In general, these motors have a high efficiency. Applications for these motors include precision machining, robotics, ink-jet printers, and pneumatic control valving.

Thin film pyroelectric sensors for use as quick monitors of temperature are also of interest to the Japanese. Deposition is mainly accomplished by magnetron sputtering using various control parameters. The papers at the workshop discussed the effect of alkaline earth substitutions in lead titanate ceramics on their pyroelectric and piezoelectric properties. PZT was also discussed as a candidate material for thin film sensors. A significant growth in the use of thin film materials for electrooptic applications was predicted.

ACKNOWLEDGEMENTS

The authors would like to acknowledge the help of a number of the other participants at this Workshop for their aid in identifying the key Japanese research and development areas, particularly Manfred Kahn, Harlan Anderson, Relva Buchanan, and Eric Cross.

The Third U.S.: Japan Seminar on Dielectric and Piezoelectric Ceramics

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PROGRAM and ABSTRACTS

Co-chairman T. Yamaguchi, Keio University Co-chairman S. W. Freiman, National Bureau of Standards

Chairman of Program Committee, H. Banno, NGK Spark Plug Co. Chairman of Financial Committee, K. Wakino, Murata MFG. Co. Chairman of Tour Committee, N. Ichinose, Waseda University Chairman of Executive Committee, A. Okamoto, TDK Electronics Secretary, T. Kimura, Keio University

November 9-12, 1986 YKK Conference Hall Toyama, Japan

Sunday 9th November 1986

4:00 pm	Registration	(NEW OTANI HOTEL)
to		
6:00 pm		
6:00 pm	Dinner	
7:30 pm	Cocktail Party: Recception	
	Monday 10th November 1986	
8:30 am	(Bus leaves Hotel)	(1997. 2. 6
9:20 am	Welcome to 3rd U.S:Japan Seminar	(YKK Conference Hall) K. Wakino Murata MFG. Co.
	Opening Remarks	S. Freiman, NBS
	Announcements	T. Yamaguchi, Keio Univ
	Technical Program	
	Overviews	
9:40 am	Perspectives on Dielectric and Pie L. E. Cross, Penn State Univ.	zoelectric Ceramics
10:40 am	Coffee	
11:00 am		
TI:00 am	Recent Progress of Electronic Cera N. Ichinose, Waseda Univ., I. Saka	
12:00 am	N. Ichinose, Waseda Univ., I. Saka Lunch	mics in Japan be, Murata MGF. Co.
	N. Ichinose, Waseda Univ., I. Saka	mics in Japan be, Murata MGF. Co.
12:00 am	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I	mics in Japan be, Murata MGF. Co.
12:00 am	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dieletrics I	mics in Japan be, Murata MGF. Co.
12:00 am 11:30 pm	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I	mics in Japan be, Murata MGF. Co.
	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dieletrics I	mics in Japan be, Murata MGF. Co.
12:00 am	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dieletrics I	mics in Japan be, Murata MGF. Co.
12:00 am 1:30 pm 5:00 pm	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dielectrics I (Bus leaves YKK) Dinner	mics in Japan be, Murata MGF. Co.
12:00 am 1:30 pm 5:00 pm	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dieletrics I (Bus leaves YKK) Dinner Roundtable Discussions	mics in Japan be, Murata MGF. Co.
12:00 am 1:30 pm 5:00 pm	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dielectrics I (Bus leaves YKK) Dinner	mics in Japan be, Murata MGF. Co.
12:00 am 1:30 pm 5:00 pm	N. Ichinose, Waseda Univ., I. Saka Lunch Poster Session I Processing and Dieletrics I (Bus leaves YKK) Dinner Roundtable Discussions Mechanical Properties	mics in Japan be, Murata MGF. Co.

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TECHNICAL PROGRAM

U.S.: JAPAN SEMINAR ON DIELECTRIC AND PIEZOELECTRIC CERAMICS NOVEMBEER 9-12, 1986, TOYAMA, JAPAN

Overviews (Monday Morning) Session Chair: S. Shirasaki(NIRIM)

"Perspectives on Dielectric and Piezoelectric Ceeramics"

- L. E. Cross, Pennsylvania State University, Materials Research Lab.
- "Recent Progress of Electronic Ceramics in Japan"
- N. Ichinose, Waseda University
- I. Sakabe, Murata MFG Co. Ltd.

Roundtable Discussions (Monday Evening)

- 1) Mechanical Properties: S. W. Freiman, B. Koepke and R. C. Pohanka,
- K. Niihara and K. Uchino
- 2) Piezoelectrics: L. E. Cross, J. Dougherty, M. P. Harmer, N. Ichinose and H. Takekuchi
- 3) Dielectrics: I. Burn, H. U. Anderson, D. Payne, D. A. Smyth,
- H. Yanagida and K. Wakino
- 4) Processing: R. Buchanan, G. Haertling, R. W. Vest, T. Yamaguchi and
- S. Hirano

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Poster Sessions

Poster Session I (Monday Afternoon) Session Chair; D. A. Payne (Univ. of Illinois), S. Hirano (Nagoya Univ.)
Processing and Dielectrics I

Poster Session II (Tuesday Morning) Session Chair; R. C. Pohanka(ONR), H. Yanagida(Tokyo Univ.)
Dielectrics II, Pyroelectrics, Mechanical Properties and Electro-optic and PLZT

Poster Session III (Wednesday Morning) Session Chair; W. A. Schultz(Alfred Univ.), K. Uchino(Sophia Univ.)

Piezoelectrics, Actuator and Miscellaneous

Tuesday 11th November 1986

8:00 am	(Bus leaves Hotel)	
		(YKK Conference Hall)
8:50 am	Poster Session II DielectricsII, Pyroelectrics, Mecha Electro-optic and PLZT	nical Properties and
12:00 am		
1:45 pm	(Bus leaves YKK) (Bus leaves Hotel) Excursion	(1)
6:30 pm	Party : Courtesy of DuPont Japan	(NEW OTANI HOTEL)
	Wednesday 12th November 1986	
8:30 am	(Bus leaves Hotel)	YKK Conference Hall
9:20 am	Poster Session III Piezoelectrics, Actuator and Others	
12:00 am	•	K. Okazaki Nat. Defense Acad.
	Farewell Party: Courtesy of YKK	
	U. S. Reflection Meeting	

Poster Session I (Monday Afternoon)

Processing

- Sol-Gel Processing of PbTiO2, PZT and PLZT D. A. Payne, K. D. Budd and S. K. Dey, University of Illinois
- Preparation and Properties of Ferroelectric Films from M-2Metallo-organic Precursors R. W. Vest, Purdue University
- Faurication of Grain-Orientated KSr₂Nb₅O₁₅ Ceramics M-3
- T. Kimura, Y. Ogino and T. Yamaguchi, Keio University Properties of Sub-micron BaTiO₃ with Additives for Low M-4Firing Temperature K. Abe, M. Aoki, K. Fukai and K. Hidaka, Sakai Chemical Industry Co., Ltd.
- Effect of MgTiO3 on the Grain Growth of M-5
- (Ba,Ca)(Ti,Zr)03 Ceramics S. Itoh, T. Noguchi and T. Ogasawara, TDK Corporation Machining of PZT,PT, and (MnZn)Fe₂O₄ Ceramics by Laser-M - 6
- Induced Chemical Etching T. Shiosaki and A. Kawabata, Kyoto University
- Synthesis and Projecties of Alkoxy-derived ZrxTiySnzO. M-7Ceramics S. Hirano, T. Hayashi and A. Hattori, Nagoya University
- Effect of Agglomerated Particles on Properties of M-8 Ceramic Green Sheets T. Ueyama N. Kaneko and Y. Machii, Hitachi Chemical Co.,
- M-9 Sinterability of High-Packing Density BaTiO₃ Green Sheets T. Ueyama, S. Yamana and N. Kaneko, Hitachi Chemical Co., Ltd.

Dielectrics I

- M-10 An Investigation of the Low Voltage Failure Mechanism in Multilayer Ceramic Capacitors C. J. Brannon and H. U. Anderson, University of Missouri-Rolla
- M-11 Additive Effects on Microstructure and Properties of BaTiO₃ R. Buchanan, University of Illinois
- M-12 Barium Titanate-Based Dielectrics for MLC's with High K
- and Low Firing Temperature
 I. Burn and M. T. Secaur, E. I. du Pont de Nemours & Co.
 M-13 Electrical Conduction in BaTiO₃-Based Ceramic L. C. Burton and H. Y. Lee, Virginia Polytechnie Institute

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- and State University M-14 Dielectric and Piezoelectric Ceramics Historical Developments: Current Status and Future Prospects
- L. E. Cross, Pennsylvania State University M-15 Operationally Induced Thermal Stress gradients in Multilayar Capacitors
- J. Dougherty, Advanced Materials Technologies
- M-16 Microstructure and Nanostructures of Relaxor Ferroelectrics M. P. Harmer, Lehigh University
- M-17 Dielectric Properties of Fine-Grained BaTiO₃ Derived From BaTiO(C2O4).4H2O
- T. Enomoto, T. Uno and N. Okada, Central Glass Co., Ltd. M-18 Low Temperature Fired Glass-Ceramics Dielectric Material

W-7 Electromechanical Properties of Planar Vibrational mode in PET/Polymer Piezoelectric Composites
H. Takeuchi and C. Nakaya, Hitachi Ltd.

H. Takeuchi and C. Nakaya, Hitachi Ltd.
W-3 Amisotropic Piezoelectric Coupling Factor of
[Pbx(Bio.,Nao.,),...]TiO, Ceramics
S. Tashiro, Y. Oikawa, H. Igarashi and K. Okazaki,

National Defense Academy

W-9 Effects of Shape and Volume Fraction of Closed Pore on Dielectric Loss, Mechanical Quality Factor and Electromechanical Coupling Factor of Dielectric and Piezoelectric Ceramics-A Theoretical Approach-H. Banno, NGK Spark Plug Co., Ltd.

Actuator

W-10 Efficiency of Piezoelectric Ceramic Actuator S. Takahashi, NEC Corp.

W-11 Ceramic Green Sheet Puncher Using Piezoelectric Actuator T. Yoshiura, K. Yoshida, I. Kagaya, Y. Shimada and S.

Takahashi, NEC Corp.

W-12 Monomorph Actuators Using Semiconductive Feffoelectrics K. Uchino, M. Yoshizaki, H. Yamamura*, K. Kasai*, N. Sakai* and H. Asakura*, Sophia University, *Toyo Soda Manufacturing Co., Ltd.

W-13 Development of Electrostrictive Ceramics S. Jomura and K. Maruta, Hitachi Metals Co., Ltd.

W-14 Temperature Dependence of Electrostriction Under a High Electric Field K. Abe., O. Furukawa, M. Katura and K. Inagaki* Toshiba Corp, *Marucon Electronics Co. Ltd.

W-15 Proparation and Characteristics of New Monomorph Actuator N. Sakai, K. Kasai and H. Yamamura, Toyo Soda Manufacturing Co., Ltd.

Miscellaneous

W-16 Laser Patterning of Polymers for Electronic Packaging H. S. Cole, Y. S. Liu, H. R. Philipp and L. M. Levinson, Gerneral Electric Corporate Research and Development

W-17 Characterization of the Role of Excess Magnesium Oxide and Lead Oxide in Lead Magnesium Niobate

H. C. Wang and W. A. Schulze, Alfred University

W-18 Trivalent Impurities in BaTiO₃
K. Takada, R. Y. Lee. S. R. Witek and D. M. Smyth, Lehigh University

W-19 Line-focus-beam Acoustic Microscope System for Nondestructive Evaluation of Acoustic Inhomogeneity on PTZ Wafer for SAW Devices

N. Chubachi and J. Kushibiki, Tohoku University

W-20 Electrical Peoperties of (Sr,Ca)TiO₃ Based Ceramic Varistors
M. Masuyama, J. Funayama and N. Yamaoka, Taiyo Yuden Co., Ltd.

W-21 Defect Structure and Electrical Property of La-Doped Barium Titanate S. Shirasaki, H. Haneda and M. Sugimoto*, National Institute for Research in Inorganic Materials, *TDK Corp.

W-22 Determination of a Compositional Fluctation in Perovskite Ternary Systems

K. Kakegawa and Y. Sasaki, Chiba University

W-23 Properties of AlN Ceramics T. Takahashi, K. Anzai, N. Takada and K. Shinozaki, New Materials Department, Toshiba Corp. CONTRACTOR DESCRIPTION DESCRIPTION DE LA CONTRACTOR DE LA

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M. Takabatake, K. Kawakami and M. Sakai, Asahi Glass Co.
M-19 Low Temperature Fired Multilayer Ceramic Capacitor with Ni
Electrodes
H. Kishi, T. Wada, S. Murai and H. Chazono, and
N.Yamaoka, Taiyo Yuden Co., LTD.

M-20 Barium Titanate Ceramics for Base Metal Monolithic Ceramic Capacitors Y. Sakabe, T. Takagi and K. Wakino, Murata Manufacturing

Co., Ltd.
M-21 Temperature Stable Barium Titanate Ceramics for Base Metal
Mutilayer Capacitors
N. Fujikawa, N. Yokoe and F. Hamano, Kyocera Corp.

M-22 Barium Modified Lead Zinc Niobate Dielectrics for Multilayer Ceramic Capacitor K.Inagaki, Y. Yamashita and K. Yuuki, Marucon Electronics Co. Ltd.

M-23 Dielectric Relaxation Studies in Some Polymer-PZT Composites A. M. Varaprasad, Naval Dockyard, India (Sophia University)

Poster Session II (Tuesday Morning)

Dielectrics II (Microwave)

T-1 Microwave Dielectric Properties of Pb(Zr,Ce)O₃ Ceramics K. Murano, K. Tatuki, S. Nishigaki*, S.Yano*, and H. Kato*, Sony Corp., *Narumi China Corp.

T-2 High Dielectric Constant Ceramics for Microwave Resonators H. Sato, K. Ayusawa, M. Saito and K. Kawamura, OKI Electric Industry CO. Ltd.

T-3 High-Q Dielectric Resonator Material for Millimeters-Wave Frequencies
H. Tamura, D. A. Sagara, M. Murata and K. Wakino, Murata Manufacturing Co., Ltd.

T-4 Dielectric Properties of BaO-TiO, WO, System at Microwave Frequency
S. Nishigaki, S. Yano, H. Kato and T. Nonomura, Narumi China Corp.

Pyroelectrics

T-5 Ferroelectric and Pyroelectric Properties of Sputter-deposited PZT and PT Films
 M. Adachi, T. Shiosaki and A. Kawabata, Kyoto University

T-6 Pyroelectric and Electrical Properties of Modified Lead
 Titanate Ceramics
 N. Ichinose, Waseda University

T-7 Properties of Hot-Pressed Lead Germanate Silicate Ceramics K. Nagata and K. Okazaki, National Defense Academy

Mechanical Properties

T-8 Comparison: Thermal and Mechanical Properties of Barium Titanate Versus Lead Perovskite Dielectrics
A. E. Brown and C. R. Koripella, Union Carbide Corp.

T-9 Fracture Behavior of Capacitor Ceramics
S. W. Freiman and T. L. Baker, National Bureau of
Standards

T-10 Compositional Influences on PLZT Switching Properties B. Koepke, F. Wallenhorst and J. Kyonka, Honeywell Inc.

T-11 Electromechanical Failure Predictions R. C. Pohanka, P. L. Smith ans S. W. Freiman*, Office of Naval Research, "National Bureau of Standards

T-12 he Relation of Anisotropy Between Crack Length and Fracture Toughness in Poled PLZT and Modified PbTiO, Ceramics T. Yamamoto, H. Igarashi and K. Okazaki, National Defense Academy

T-13 Mechanical and Dielectric Failure of BaTiO, Ceramics A. Kishimoto, K. Koumoto and H. Yanagida, The University

T-14 Ceramic Toughning by Crack-Stacking Faults Interactions K. Niihara and T. Hirai*, National Defense Academy, Tohoku University

Electrooptics & PLZT

T-15 Electrooptic Materials for Integrated Optic Device Applications R. L. Holman, Battelle Columbus Laboratories

T-16 Growth and Applications of Tungsten Bronze Family Crystals R. R. Neurgaonkar, W. K. Cory, J. R. Oliver and W. F. Hall, Rockwell International Science Center

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4."

T-17 Photoferroelectric Effect in PLZT Ceramics G. Haertling, Motorola, Inc.

T-18 Photodriven Relay Using PLZT Ceramics K. Uchino, T. Sada and M. Inoue, Sopnia University

T-19 PLZT Thin Film on MgAl₂O₄/Si Substrate S. Matsubara, Y. Miyasaka, N. Shohata and M. Yonezawa, NEC

T-20 Some Electrooptic Properties of PLZT Ceramics K. Hikita, M. Hirama, Y. Tanaka and M. Ono, Mitsubishi Mining & Cement Co., Ltd.

T-21 Dielectric Properties of Sputtered Polycrystalline (Pb,La)(Zr,Ti)O, Thin Films K. Wasa, H. Adachi and T. Mitsuyu, Matsushita Electric Ind. Co., Ltd.

Poster Session III (Wednesday Morning)

Piezoelectrics

Preparation and Performance of Ceramic-Air Composites for Hydrostatic Sensing M. Kahn, A. Dalzell and B. Kovel, U. S. Naval Research Laboratory

W-2A Resonance Technique for Measuring the Complex Elastic, Dielectric and Piezoelectric Coefficients of Composite Materials

X. Q. Chang, A. R. Ramachandran and R. E. Newnham, Pennsylvania State University

₩**-3** Ferroelectric Composite Transducers

B. A. Auld, Stanford University

W-4 Piezoelectric Properties of Some New Hydrophone Materials R. Y. Ting, U. S. Naval Research Laboratory.

Dielectric and Piezoelectric Properties of **U-5**

PbZrO₃-PZ(Zn_{1/3}Nb_{2/3})O₃ Ceramics K. Sakata and T. Takenaka, Science University of Tokyo W-6 Piezoelectric Properties of (Na, Li)NbO₃ Ceramics T. Honda, I. Kawamata, H. Watarai and T. Ido, Mitsubishi Electric Corp.

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SOL-GEL PROCESSING OF PETIG, POT AND PLOT

D. A. PAYNE, K. D. BUDD AND S. K. DEY

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ABSTRACT: Dielectric thin-films of PbTiO $_3$ based materials were prepared by the spin-casting of a Pb,Ti-methoxyethoxide solution onto platinum, silicon and a variety of substrate materials. The resulting gel layers densified at relatively low temperatures (< 350°C) with crystallization to the perovskite phase at 450 - 700°C, depending upon composition. The films were transparent and had electric strengths in excess of 100 V/ μ m. Ferroelectric hysteresis loops were obtained for 1 μ m layers with grain sizes of 0.1 μ m. PZT 53/47 had μ = 32.5 μ C/cm 2 , with μ = 30 KV/cm; and the relative permittivity of PLZT 10/65/35 was 1700.

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1. INTRODUCTION

An upset technology is in the making for the fabrication of dielectric thin-films by polymeric sol-gel processing. This novel processing route avoids powder (and attendent problems), and produces films of exceptional quality, at relatively low temperatures. The present study reports on recent measurements on ferroelectric and dielectric properties.

2. EXPERIMENTAL

2.1 Materials

Precursor solutions of a complex Pb-Ti alkoxide were prepared by reacting lead acetate with titanium isopropoxide in methoxyethanol. A complex Pb,Ti-methoxyethoxide formed by alcohol exchange with Ti-isopropoxide, and subsequent reaction with a dehydrated Pb-acetate solution. Alkoxides of 2r and La were also incorporated into the system. The importance of hydrolysis conditions, condensation reactions, and thermal processing conditions, on film formation and microstructure development, are summarized in reference 2.

A parallel-plate capacitor geometry was used to determine relative permittivities, dissipation factors, and electric strengths. The counter electrodes were sputtered gold. Scaling of capacitance with area was taken to be a proper indication of the absence of contact problems. Hysteresis measurements were made on a modified Sawyer-Tower Circuit.

3. RESULTS

Table 1 summarizes relative permittivities and dissipation factors for solgel derived films on Pt. The results are in good agreement with values reported in the literature for bulk samples and hot-pressed parts. Figure 1 illustrates the dependence of relative permittivity on heat treatment

a) Details of the processing route are given in references 1 and 2.

conditions and crystallization behavior. The dielectric strengths were in excess of $10^8~{\rm V/m}$. Hysteresis loops were observed, confirming ferroelectricity (Figure 2).

4. DISCUSSION

Sol-gel processing is an attractive method for the fabrication of high quality thin-films of complex dielectric materials. Applications include the direct integration of capacitors onto semiconductors and substrates, piezoelectric and ferroelectric devices, and optical connectors.

Table 1. Dielectric Properties of Sol-Gel Derived Thin-Films

composition	crystallinity	permittivity	dissipation factor
PbTi03	amorphous	28 - 42	0.003 - 0.010
PbT103	crystalline	155 - 185	0.006 - 0.030
PZT 53/47	amorphous	35	0.005 - 0.010
PET 53/47	crystalline	300 - 1200	0.020 - 0.670
PLZT 10/65/35	amorphous	35	0.005 - 0.010
PL2T 10/65/35	crystalline	300 - 1700	0.020 - 0.090

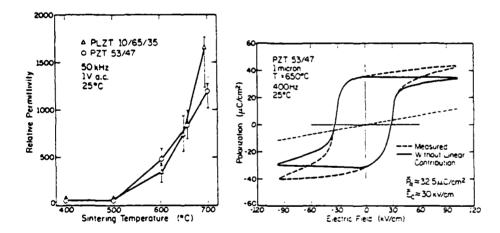


Fig. 1. Effect of heat-treatment on permittivity of high-K thin films.

Fig. 2. Ferroelectric hysteresis for PZT 53/47, 1 µm thin-film.

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ACKNOWLEDGEMENTS

This work was supported by the U.S. Department of Energy, Division of Materials Sciences, under contract DE-AC02-76SR01198.

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M-2

PREPARATION AND PROPERTIES OF FERROELECTRIC FILMS FROM METALLO-ORGANIC PRECURSORS

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ABSTRACT: Ferroelectric PbTiO $_3$ and (PbSr)TiO $_3$ films 0.5 to 5.0 μ m thick were prepared by the metallo-organic decomposition (MOD) process using multilayer spinning with firing temperatures of 490 to 700°C. Both Pt and ITO electrodes were also prepared by the MOD process, and dielectric properties were measured as a function of temperature. The films were near theoretical density and defect free over 2 cm × 2 cm areas.

1. INTRODUCTION

The MOD process for preparing ferroelectric films has a number of advantages over conventional processes. These include rapid formation of compounds in films and lower temperature processing of equilibrium phases.

2. EXPERIMENTAL

Lead neodecanoate $\{Pb(C_9H_{19}COO)_2\}$, strontium neodecanoate $\{Sr(C_9H_{19}COO)_2\}$ and titanium di-methoxy-di-neodecanoate $\{(CH_3O)_2Ti(C_9H_{19}COO)_2\}$ were the precursors used for the ferroelectric films. These compounds were dissolved in an appropriate solvent, the solutions mixed to achieve the desired stoichiometry, and the resulting solution spun onto substrates which had previously been provided with Pt or ITO electrodes by the MOD process. The samples were fired at a programmed rate to temperatures from 490 to 700°C, either with or without an electric field present.

The crystal structure was studied using x-ray diffraction analyses, and the microstructure was studied using SEM and TEM. The temperature dependences of D.C. resistivity, dielectric constant, dissipation factor and spontaneous polarization were measured.

3. RESULTS AND DISCUSSION

For a given time-temperature profile, it was determined that the film must be below some critical thickness in order to sustain the volume change of as much as a faltor of 30 without cracking. It was shown that multiple spinning and firing of films below this critical thickness can be used to produce any desired final film thickness. The reliability for the specimens, defined as the percent of the 143 planner capacitors in a 4 cm² area which gave equivalent dielectric properties with an applied field of 100 kV/cm, was found to depend on factors such as the choice of substrate, the purity of the metallo-organic precursors, and the process cleanliness in addition to the time-temperature firing profile and the single layer thickness. Currently, 2 cm × 2 cm dielectric films can be made with 100 percent reliability if all these factors are properly controlled.

It was found that the mainstax for FiTib_3 tilms varied with the firing temperature and with single later thickness, but in all haves was smaller than that of bulk tetragenar ${\rm PbTi}\nu_3$. For the same thickness ${\rm ToTi}\nu_3$ tilms fired at the same temperature, it was found that the c/a values for those films fired in a D.C. electric filed at temperatures below $T_{\rm c}$ were smaller compared to those fired without a field, and that the effect increased with increasing field strength.

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The grain size of the PhTiO $_3$ films was found to increase with increasing firing temperature and single layer thickness, but in all cases was very small (14 to 25 nm). This small grain size was responsible for the small spontaneous polarization ($^{5}\mu\text{C/cm}^2$) values observed. At lower firing temperatures ($^{5}50^{\circ}\text{C}$), the grain orientation in polycrystalline tetragonal films was random. For firing temperatures higher than 600°C , a strong tendency for preferred orientation with the classis perpendicular to the substrate surface was observed.

The dielectric constant of the PbTio $_3$ films was 100 \sim 110 at temperatures below 300°C, and reached a maximum value of $3*10^4$ at the Curie point (493 to 495°C). The dissipation factor remained almost constant until 250°C and then increased rapidly with further increase in temperature. The temperature dependence of dielectric constant was found to be a function of the c/a ratio, which could be modified by either control of the single layer thickness or the strength of an applied D.C. field during film preparation below the Curie temperature. The dielectric strength for 0.5 to 2.0 µm thick films was greater than 100 kV/cm.

Solid solutions of PbTiO $_3$ and SrTiO $_3$ were formed, and compositions to give $T_{\rm c}$ in the neighborhood of room temperature were extensively studied. The dielectric constant was found to be a strong function of electric field for these films.

M-3

FABRICATION OF GRAIN-ORIENTED KSr_Nb_GO15 CERAMICS

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ABSTRACT: The morphology of powder particles obtained by molten salt synthesis was examined for alkali-alkaline earth niobate ${\rm AB_2Nb_5O_{15}}$, where A=Na or K and B=Sr or Ba. Rod-like particles suitable for the preparation of grain-oriented ceramics were obtained in ${\rm KSr_2Nb_5O_{15}}$. The crystallographic direction of the rod-axis was determined to be [001] by X-ray diffraction analysis of extruded and sintered compacts.

1. INTRODUCTION

Grain-oriented ceramics are prepared by normal sintering of plate- or rod-like powders made by molten salt synthesis. Alukali-alkaline earth niobate $AB_2Nb_5O_{15}$ (A and B are alkali and lakaline earth ions respectively) has tetragonal tungsten bronze-related structure and its polar axis is parallel to [001]. Particle morphology depends on the anisotropy of growth rate in molten salt. Rod-like powder particles with rod-axis parallel to [001] are suitable for preparing grain-oriented ceramics. This paper deals with the preparation of $AB_2Nb_5O_{15}$ (A=Na or K; B=Sr or Ba) powders in the presence of molten chloride.

2. EXPERIMENTAL

Mixtures of alkali carbonate A_2CO_3 , alkaline earth carbonate BCO_3 , niobium oxide Nb_2O_3 and alkali chloride ACl were heated at a desired temperature between 700° and 1200°C for lh. The products were washed with hot water to remove the chloride. The crystalline phases and morphology of the resultant powders were examined by X-ray diffraction analysis (XRD) and scanning electron microscopy (SEM) respectively.

Rod-like $KSr_2Nb_5O_{15}$ powder particles were mixed with methyl cellulose, polyethylene oxide and water in a roll-mill and extruded through a nozzle 1 mm in diameter. The resulting rods were cut to 3 cm long rods, which were aligned in a square die (3x3 cm) and pressed at 98 MPa. The compacts were cut to small pieces (1x1x0.2 cm) and heated slowly up to 500°C in air to burn out the organic ingredients. The green compact was sintered at 1350°C for 1h. Orientation of particles and grains in green and sintered compacts was wxamined by XRD.

3. RESULTS AND DISCUSSION

Particle morphology of the powders obtained at 1200°C was examined by SEM. For ${\rm NaSr_2Nb_5O_{15}}$ and ${\rm NaBa_2Nb_5O_{15}}$, mixtures of rod-like and equiaxed particles were obtained. For ${\rm KSr_2Nb_5O_{15}}$ and ${\rm KBa_2Nb_5O_{15}}$, the powders consisted of only rod-like particles. ${\rm KSr_2Nb_5O_{15}}$ particles were selected because of their large aspect ratio.

Figure la shows the XRD pattern of a green compact made by extruding of the rod-like powder. Comparison with the XRD pattern for equiaxed powder (Fig. 1b. indicates that intensities of (230), (400) and (140) for the compact of the rod-

like powder are larger than those for the equivaled bewaler. Sim observation of the compact revealed that many particles aligned with their mechanis parameter to the extrusion direction. These results indicate that the thomaxis is parallel to [001].

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Figure 2 shows the XRD patterns of a sintered compact. Sintering increased the intensities of (hk0) reflections from the plane parallel to the extrusion direction (compare Figs. la and 2a). Only (001) and (002) were intense peaks from the plane perpendicular to the extrusion direction. The sintered compact was characterized by anisotropic microstructure; the rod-like grains were aligned in the direction parallel to the extrusion direction. These results indicate that grain-oriented ceramics with aligned polar axis are obtained.

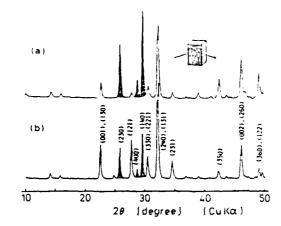


Fig. 1 X-ray diffraction patterns of (a) green compact and (b) equiaxed powder.

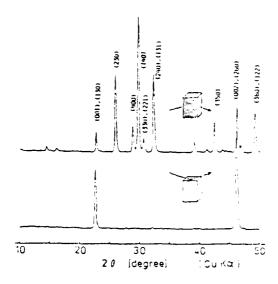


Fig. 2 X-ray diffraction patterns of sintered compact.

M-4

PROPERTIES OF SUB-MICRON BATIO3 WITH ADDITIVES FOR LOW FIFING TEMPERATURE

ACCOMPANABLY COCCOSION NOCCOSION REPRESENTATIONS DE COCCOSION

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ABSTRACT: Sintering properties, electrical properties and crystal structure of three kind of BaTiO3 with an additive for low firing temperature were studied.

Comparisons were made among three powder production methods, i.e. the hydrothermal synthesis method, the oxalate method and the calcination method, and among various additives for low firing temperature. As a result, it was found that the hydrothermal synthesis method provides the most excellent sintering and electrical properties for BaTiO3 with an additive for low firing temperature.

1. INTRODUCTION

Payne et al. and Chowdary et al. attempted to reduce firing temperature by adding glassy materials to BaTiO3 powder. It is expected that sintering temperature will be further reduced by adding such an additive for low firing temperature to easing sinterable BaTiO3 cotained by the hydrothermal synthesis method.

2. EXPERIMENTAL

2.1. Sample Powders and additives

The following three BaTiO3 powders were used as samples:

- 1) Powder produced by the hydrothermal synthesis method
- 2) Commercially available powder produced by the oxalate method
- 3) Powder produced by the calcination method, which is calcined at 1150° C using high-purity fine BaCO3 and TiO2 (both Sakai Chemical).

Five kinds of additives (A,B,C,D,E) were used. Each additive was added to each BaTiO3 in a specified amount(see table 2). Mixing was carried out in a polyethylene pot containing zirconia balls and acetone overnight.

2.2 Measurement

After sample powders were granulated, 2.2g of the granules were placed in dies 20mm in diameter, pressed 1000 kg/cm for 1min. Resulting green molds were fired for 3 hours at specified temperature between 800°C and 1300°C . Fired products were subjected to measurement of sintered density electrical properties.

3. RESULTS AND DISCUSSION

Properties of BaTiO3 powders without an additive are shown in Table 1. Table 1 shows that there are no significant differences among the three in

purity, although the powder produced by the hydrothermal synthesis is the most excellent in particle shape (spherical), fine particle size ($0.1\mu m$) and particle size distribution (uniform).

Figures 1-3 show typical temperature dependence of sintered density. As shown in these figures, the BaTiO3 powder produced by the hydrothermal synthesis method is the most easily sinterable independent of whether or not an additive is added. Based on this finding, it is thought that the low temperature sinterability of the main raw material rather than the effect of additives is an important factor for low temperature firing.

Table 3 shows electrical properties of sintered products obtained at minimum firing temperature for sintering. As shown in this table, it is found that additive A is a most effective additive for low firing temperature, because this additive makes it possible to perform sintering at 1000°C even though it is added in a small amount (1.0 mol%), thus having a less effect on electrical properties of the sintered product.

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37, 689-692 (1981)

Table 1 powder properties						
me thod	Hydrothermal	Oxalate	Callination			
BET surface area (mi/g)	12	2. 2	1.0			
Bulk density	0.59	0.72	0.83			
1EM ecan particle size (##)	0 . 1	0.3	1.2			
Ra/Ti mol ratio	1.01	1 00	1.01			

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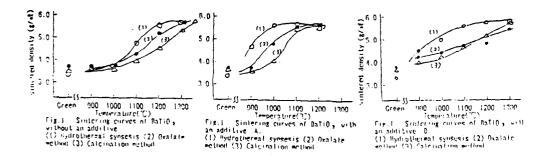


Table 3 Properties of sintered products obtained at minimum fixing Lemmerature necessary for sintering. # Archiendes's method

Production	Arfelo (1 ve	Firing Te- Appraisure	Sintered density (f./ef)	Grain Size (µ)	c 20°C (at Ikiiz)	7an 8 (al (bli2)	Curie noint (T)	£ tat (at Tallz)	Receiving (Q · cm)
Mydentherest Synthesis	191	1200	5 83	2 1	3558	0.91	125	5100	1 2×10"
.,,.,.	^	1000	5 82	0.8	2917	1.10	122	3783	2 1~10"
	9	1100	5 50	0 3	1218	3.27	110	2005	ייפו את נ
Usa late		:100	5 83	13	3117	3 29	120	10188	8.7×10"
	_ ^	1100	5 78	2 9	2930	: 21	127	1846	1.5×10*
	0	1,100	5 53	2 8	1712	2 87	129	9564	2.5×10.
Calcination setted	110	1750	5.81	77	2018	1 51	121	רבוע	1.0×:012
	<u> </u>	1100	5.05	12	2110	1 12	:16	6210	2 0 4 1013
i	[5]	ור פררו	5.81	2.5	1477	3 01		ומיני	3 7 17 17

M-5

EFFECT OF MgTiO, ON THE GRAIN GROWTH OF (Ba,Ca) (T1,Zr)O, CERAMICS

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1. INTRODUCTION

For the manufacturing of ceramics, it is important to clarify the relation between characteristics and phenomena which occures during firing. In $\{Ba, Ca\}$ $\{Ti, Zr\}O_3$ ceramics, which is widely used for ceramic capacitors, we have investigated the effect of $MgTiO_3$ and microstructural changes during firing. And we have found that the final grain size was strongly depend on the firing profile, especially on the cooling curve.

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2. EXPERIMENTAL

2.1. Samples

The composition and the preparation method of samples are shown in Table-I. 2.2. Rapid Cooling Experiments

Samples were fired along the temperature profile shown in Fig.1, and were air quenched from various points of this profile. Microstructural changes were examined to those samples by SEM and EPMA.

3. RESULTS AND DISCUSSION

From the result shown in Fig.1, it was found that the addition of MgTiO₃ retards the grain growth, and grain growth was occurred at cooling zone in sample B. Photo 1 (a) and (b) shows the microstructure of samples containing 4% MgTiO₃ quenched from 1380 °C and 1250 °C respectively. Photo 1 (a) shows second phase, which is observed as dark phase, wets grains and exists at grain boundary. On the contrary, in the sample quenched from 1250 °C (Photo 1 (b)), the second phase was observed as a granule. Fig.2, shows the change of the angle of contact between matrix and this second phase. Fig.3, shows the DTA data of sample C at cooling zone and it was found that exsonthermic process was occurred.

From these results, we inferred that this second phase was liquid at high temperature (T_1) and grains were surrounded by this liquid, at cooling zone (T_2) , this liquid was solidified and disappear from grain boundary, so grain growth was occurred.

Table 1. a) Composition of samples (mol%)

Sample	BaT: O.1	3a2rQ.(_ÇaT:C₃	Mat O.
	80.0	5_1	8.5	3
B	7.70	1:0	3.Q	
Ĵ.	400	6.0	4 .0	£30

b) Preparation method of samples

raw_materwist Baction Tich	
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<u> </u>	5 - 13 - 17 - 13
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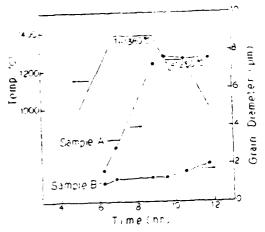


Fig.i. Change of grain sizes of sample A and 8 by Rapid Cooling Experiment

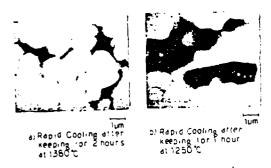


Photo 1. Microstructures of sample 8 observed by SEM (Composition Image)

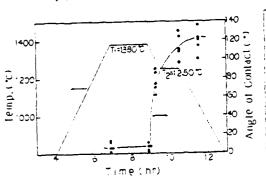
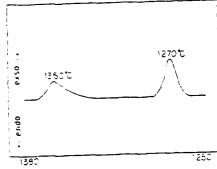


Fig.2. Angle of contact by Rapid Cooling Experiment (sample B)



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Fig.3. DTA data during cooling (sample C)

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- Mat Res Bull . 12 . 1221-1<u>226</u>
- 2 C Henning and 4 Schrell ... Julian Ceram Suc 185. 539-544 (1982)

MACHINING OF PZT, PT, AND (Mm, Zm)Fe204 CERAMICS BY LASER-INDUCED CHEMICAL ETCHING

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ABSTRACT: Laser-enhanced chemical etching of $PbT10_3$, PZT and (Mn-Zn)-ferrite ceramics is reported. The KOH solution of 10 mol/l is suitable for the laser enhanced intergranular etching of the $PbT10_3$ and PZT with depth etching rate higher than 100 µm/s in the initial laser irradiation period of Ar^+ laser of 1W output. The KOH and NaOH solutions are also suitable for the intergranular etching of (Mn-Zn)-ferrite. The H_3PO_4 solution of 6 mol/l is suitable for the laser enhanced trans-granular etching of (Mn-Zn)-ferrite with the depth etching rate of about 10 µm/s in the initial irradiation neriod of an Ar^+ laser of 1W output.

1. INTRODUCTION

A number of interesting new schemes for localized etching of semiconductors and ceramics using lasers have been reported over the last years. The laser plays a dual role in the etching process through the thermal or optical excitation to the etchant and/or workpiece. The one is to initiate or enhance the etching process and the other is to define the etch pattern by the area irradiated.

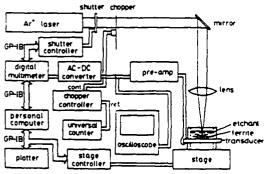


Fig. 1 Experimental set-up for laser-induced chemical etching. The photo-acoustic emission detected by the transducer is used for the automatic focussing.

In the present paper, the laser enhanced etching of ceramics of PT; $(Pb_{0.76}Ca_{0.24})$ $(Ti_{0.96}(Co_{1/2}K_{1/2})_{0.04})O_3$ from Toshiba, $PZT; Pb(Sn_{1/2}Sb_{1/2})_{0.05}Ti_{0.4}7Zr_{0.48}O_3$ from Murata, and Mn-Zn ferrite $(Fe_{2}O_{3}$ 52.4 mol%, MnO 26.5 mol%, ZnO 21.1mol%) from Sumitomo Special Metal in alkaline and acid solutions without external electromotive driving sources is described.

2. EXPERIMENTAL

Figure 1 is the set-up for the laser enhanced etching. When a new material is introduced as a new workpiece of the laser enhanced etching, experiments are started with the selection of etchants and their concentration. The depth and width etching rates are measured for various laser output power levels (maximum 1W) and the surface morphology and appearance of etched holes and slots are examined in several etchants and in air and a pure water.

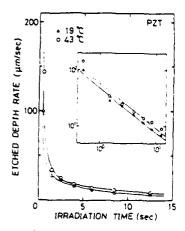


Fig.2 The relation between the laser-induced etching rate and the laser irradiation time. The laser output is 1W and the focal length of the lens is 30mm. KOH solution is 10mol/1.

3. KER1175

The etching rates of the PT and PZI without laser irradiation in 10 mol, 1 Koll which is the most suitable etchant for these are almost equal and less than 3 x $10^{-5}\, \mathrm{Lm/z}$. This means area without laser irradiation remains virtually unchanged during the process. The relation between the laser irradiation time and etched depth rate for PZT is shown in Fig.2. The etching rate is enhanced from less than 3 x $10^{-5}\, \mathrm{\mu m/s}$ to 150 $\mathrm{\mu m/s}$ by 5 x 10^6 times.

The scanning electron micrographs of laser machined workpieces show that the hole made in air has a peripherally smooth contour with some voids typical of a material that has once melted and refrozen. The upper periphery of the hole is surrounded by a ridge of refrozen material. The results when the laser is incident on the sample submerged in water are similar to those in air, but somewhat less material is removed. The dimpling and splashing of materials on the surface indicates local melting and refraezing. In both machining in air and water, cracks are frequently observed after laser irradiation. All the acid etchants are not suitable because their etching rate is low, machined surface appearance is not good. and the acid gas is vaporized and condensed on the lens. Only in the presence of $\ensuremath{\mathsf{KOH}}$ around 10 mol/l in water, the hole wall is uniform in texture, and the top surface at the hole's periphery is smooth and even, both being similar to the texture of the unetched surface of the ceramics. Similarly, slots etched in the 10 mol/1 KOH solution contain no lip or melied and refrozen ridges in contrast to those formed in air or water. The 10 mol/1 KOM solution gives the highest etching rate and excellent surface appearances. Taking all the results into account, 10 mol/1 EOH water solution is decided to be the most suitable etchant for the Ar^+ laser etching of the present PZT and PT.

The X-ray diffraction pattern of the powders which are collected from the etchant

after laser enhanced etching it 12% is shown in Fig. 3, together with the pattern to inthe PZT ceramic plate. These patterns are identical and show that the laser enhanced etching is an inter-granular etching bettemoving the ceramic grains one after another and not by melting, dissolving or vaporizing the grains. This inter-granular etching mechanism is confirmed by observing the etched surface of PZT ceramics.

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The above mentioned inter-granular etching mechanism takes place also in the laser enhanced etching of the (Mn-Zn)-ferrite in the NaOH solution. The laser enhanced etching of (Mn-Zn)-ferrite ceramic in $\rm H_3PO_4$ solution is concluded as trans-granular etching by observing the etched surface. The $\rm H_3PO_4$ solution is known as a mirror etchant of the (Mn-Zn)-ferrite ceramic.

The piezoelectric and magnetic properties are supposed to remain unchanged because the surface temperature is kept below the boiling point around 100° C of etchants and the grains are not melted.

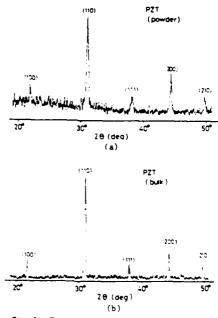


Fig. 3 The X-ray diffraction patterns of the powders (a) and bulk (b) of P2T. The P2T powders are collected from the etchant.

M-7

SYNTHESIS AND PROPERTIES OF ALKOXY-DERIVED $2r_{\chi}T_{1\chi}Sn_{z}O_{4}$ CERAMICS

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ABSTRACT: Monosized spherical particles of $\mathrm{Zr_xTi_ySn_2O_4}$ (x+y+z= 2) with an average diameter of about 0.3 µm were synthesized by the controlled hydrolysis of alkoxides. The as-prepared particles were formed directly without any sintering aid and sintered into bodies with > 96.0 % of theoretical density at 1600°C for 3 hrs. The pure sintered body of $\mathrm{Zr_{0.80}TiSn_{0.20}O_4}$ showed the dielectric constant of about 40 and the Q value of about 5300 at 10 GHz.

1. INTRODUCTION

Many kinds of dielectric materials have been developed for microwave applications. Among them, the compound in the system Zr-Ti-Sn-0, Zr_XTi_ySn₂O₄ (x+y+z= 2), is known to have a high dielectric constant, a low dielectric loss and a low temperature coefficient of resonance frequency¹⁾. The compound has been sintered with the sintering aids like ZnO, NiO, Fe₂O₃ and La₂O₃^{1,2)}.

This study was carried out in order to characterize the monosized spherical particles of $2r_x Ti_y Sn_z O_{\frac{1}{2}}$ (y=1) prepared by the controlled hydrolysis of metal alkoxides from the view-point of the dielectric properties.

2. EXPERIMENTAL PROCEDURE

Zirconium n-propoxide, titanium isopropoxide and tin isopropoxide were weighed in desired amounts according to the formula $\rm Zr_{x}Ti_{y}Sn_{z}O_{4}$ and were mixed into absolute n-propanol. The mixture of alkoxides was refluxed in dry $\rm N_{2}$ for 24 hrs and then hydrolyzed at a refluxing temperature or room temperature. The precipitates were aged and ultrafiltered. The amorphous as-precipitated $\rm ZrTiO_{4}$ and $\rm Zr_{x}Ti_{y}Sn_{z}O_{4}$ were calcined for 5 hrs at the crystallization temperature of 700°C and 650°C, respectively, and then pressed into the disks, or pressed into the disks directly and then preheated at 690°C for 5 hrs, followed by sintering at 1600°C for 3 hrs. The dielectric properties of dense sintered bodies at microwave frequency were measured by the resonant cavity method in $\rm TE_{016}$.

3. RESULTS AND DISCUSSION

The effect of hydrolysis conditions on the particle size and morphology of as-precipitated particles of $2r_{0..80} {
m TiSn}_{0..20} {
m O}_4$ is shown in TABLE 1. The particle size and morphology of as-precipitated particles did depend on the temperature during hydrolysis, especially for the composition of $2r_{0..80} {
m TiSn}_{0..20} {
m O}_4$. The higher the hydrolysis temperature, the size of the precipitated particles became larger. The spherical particles could be prepared by the hydrolysis of the solution at a refluxing temperature or of the lower concentration of 0.025 mol/l. The as-precipitated powders were found to be the monosized unagglomerated particles of about 0.3 um with narrow particle size distribution (Fig.).

Calcined $2rTiO_4$ powders were densified to fully dense todies by sintering at $1600\,^{\circ}\text{C}$ for 3 hrs, while the densification of $2r_{0.80}\text{TiSn}_{0.20}\text{O}_4$ particles depended strongly on the processing, i.e. the process A (as-precipitates + directly forming + crystallization + sintering) or the process B (as-precipitates + calcination + forming + sintering), as shown in TABLE 2. The density of the sintered body through the process A was higher than that through the process B, though the green densities with both processes were the same. The finer particles (0.1 - 0.2 um) yielded the higher density of the sintered body, compared with that from the powders (0.3 - 0.4 um).

Dielectric properties of the dense sintered bodies at 10 GHz are shown in TABLE 3. $Zr_{0.80}TiSn_{0.20}O_4$ ceramics showed lower dielectric constant than $ZrTiO_4$, but higher Q value of about 5300 at 10 GHz, and the lower temperature coefficient of resonance frequency of about 4 ppm/°C, which were superior to those of $ZrTiO_4$ ceramics.

TABLE 1. Effect of hydrolysis conditions on particle size and morphology of asprecipites, $\rm Zr_{0.80}^{TiSn}_{0.20}^{0.4}$

Conc. (mol/1)	Hydrolysis Temp.	Particle Size(um)	Morphology
0.05	room temp.	< 0.1	irregular
0.05	reflux	0.3-0.4	spherical
0.025 0.025	room temp. reflux	0.1-6.2 0.3-0.4	spnerical spherical

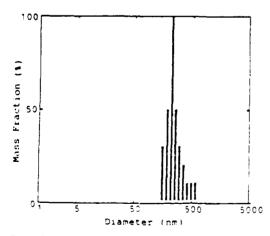


Fig. 1. Particle size distribution of alkoxy-derived $\rm Zr_xTr_ySn_zO_4$

TABLE 2. Effect of processing on sintering of Zr_{0.80}TiSn_{0.20}O₄

_			(%)
Particle	Process	Before	After
Size(um)		Sinter.	Sinter.
0.1-0.2	Α	49	96
0.3-0.4	A	55	92
0.3-0.4	В	5 5	80

*Process A; As-precipitates +
Consolidation + Crystallization
+ Sintering

Process B; As-precipitates +
 Calcination + Forming + Sintering

TABLE 3. Properties of bodies sintered at 1600°C for 3 hrs

	R.D.(%)	£r	Q	Tf(ppm/°C)
275	96	39.5	5323	3.7
275	92	35.7	5387	3.3
27	100	45.4	27.2	72.4
: :	100	45.6	5.4.	64.3

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M-8

EFFECT OF AGGLOMERATED PARTICLES ON PROPERITIES OF CERAMIC GREEN SHEETS

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ABSTRACT: Packing density of dielectric powders in ceramic green sheets was investigated. The packing density was changed by agglomerated particle size and binder content. The smaller agglomerated particle size and/or binder content is, the higher the packing density becomes.

1. INTRODUCTION

In manufacturing dielectric ceramic green sheets, it is very important to decrease scatter of packing density of green sheets. Scatter of packing density causes that of firing shrinkage. Particularly, when packing density becomes low, many pores tend to be generated in sintered body.

We have investigated slurry manufacturing technique and developed the new technique of dielectric powders. Using this technique, agglomerated particles can be pulverized primary particles without mechanical destruction, and as the result of it, scatter of packing density decrease remarkably.

In this report, the relationship between agglomerated particle size and packing density of green sheets, which are manufactured by the new manufacturing technique, is described. Moreover, the relationship between binder content and packing density of dielectric powders is discussed.

2. EXPERIMENTAL

As dielectric powders, Al_2O_3 and $BaTiO_3$ was used in this work. Table 1 and 2 gives the typical composition of green sheets.

Table 1 Typical composition of Al₂O₃ green Table 2 Typical composition of BaTiO₃ green sheets sheets

Material	weight parts	Material	weight parts	
A1203	100	BaTiO3	100	
Binder (Poly vinyl Buty rale)	6	Binder (Poly methyl methacrilat)	12.4	
Plasticizer (Bulyul Benzil	3	Plasticizer (Bulyul Benzil	1.4	
phthalate)		phthalate)		
Solvent (Chlorinated Hydrocarbon	Proper	Solvent (Chlorinated Hydrocarbon	Proper	
& Alcohol Mixture)	Quantity	& Keton Mixture)	Quantity	

Slurries were produced using new advanced ballmilling technologies. In new advanced technique, agglomerated powders can be pulverized to primary particles. Dielectric ceramic green sheets were produced by the doctor blading process.

3. Result and Discussion

3.1 Agglomerates size and packing density

Result are shown in Fig. 1, 2. When agglomerates are pulverized the packing density gradually increases, and reaches the saturation value when the size of the primary particles is attained. This value is almost equal to the packing density of 60.45 vol% calculated with monosized powders cast without pressure.

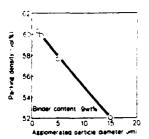


Fig 1 Relationship between agglomerated particle diameter and packing density of AQ₂O₃ green sheet

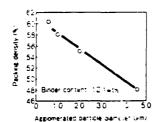
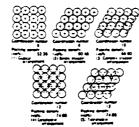


Fig 2 Relationship between aggiomerated particle diameter and packing density of BaTiO₃ green sheet

density of Al₂O, green sheet

3.2 Binder Content, Packing density and packing forms of monosized balls.

Figure 3 indicates the relation between packing arrangement and packing density of monosized balls. When monosized powders are packed without external force like doctor blading process, it can be presumed that maximum coordination number of powders is 8. Therefore, theoretically, maximum packing density of monosized powders in green sheets is 60.45 vol%, which is the value of single stagger arrangement in Fig. 3.



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Fig 3 Packing forms of monosized balls

Figure 4, 5 shows the relationship between binder content and packing density; the smaller the agglomerates diameter and/or binder content, the higher the packing density of $Al_{2}O_{3}$ and $BaTiO_{3}$ powders.

The maximum packing density of dielectric powders, which was obtained in this work, is nearly equal to this theoretical packing density of monosized powders.

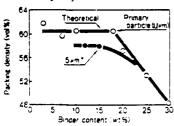


Fig 4 Relationship between binder content and packing density of A2₂O₃ green sheet

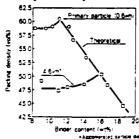


Fig.5 Relationship between binder content and packing density of BaTiO₃ green sheet

sheet 4. CONCLUSIONS

- Packing density in the green sheets increases at decreasing agglomerate size, and reaches the saturation value of 60.4 vol% when the size of agglomerates reaches the primary particle size.
- 2. The saturation value of 60.4 vol% is well matched with the packing density of 60.45 vol% corresponding to a coordination number 8 for monosized particles in single stagger arrangement.
- 3. Especially, in the case of BaTiO3 green sheet, when agglomerates are pulverized packing density reaches a maximum at a definite binder content, and decreases when the binder content deviates from this level, either downward or upward.
- 4. The packing density decrease which occurs when the binder content in the green sheets is too small is assumed to derive from a weaker bonding force of the polymethyl methacrylate binder which incompletely fills interparticle voids.

SINTERABILITY OF HIGH-PACKING DENSITY BAT103 GREEN SHEETS

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ABSTRACT: Sintering properties was discussed regarding BaTiO3 green sheets which packing densities were different. The sinterability of BaTiO3 dependent greatly on agglomerates size rather than on the packing density of powder. The larger the agglomerates size are, the more the optimum firing temperature which are vanished of open pores was shifts toward the high-temperature side, and the firing density then is diminished significantly. On the other hand, green sheets which are pulverized into primary particles have the firing density fixed at the constant value 5.8 and does not change at all even when the packing density is significantly lowered by varying the amount of binder.

1. INTRODUCTION

The low temperature sintering of dielectric ceramic is study by using fine powder and Liquid phase.

We developed technique to pulverize agglomerated fine powder gradually into primary particles in the slurry.

By using this slurry, production of green sheets which packing density is almost equal to theoretical packing density is enabled.

This report describes the relatipship between the agglomerates size and packing density and sinterability on the green sheets of BaTiO3 which was manufactured by this technique.

2. EXPERIMENTS

As dielectric material, BaTrO3 was used in this work. Table 1 gives the chemical composition of $BaTiO_3$ powder. Dielectric green sheets were produced by the doctor blading process. Samples were sintered in the range $700 - 1.300^{\circ}$ C in an atomosphere.

Table 1 Characterization of BaTiO; powder=

Item density	4	4	4	specific					57		41 0	Ompo	#:::	on		_	
	8011866	Diameter	3.	71	Po	Zn	No	Ð١	Co	5.	, Mn	Al	Sr	N:			
an i c	4/cm3	. : q								•							
PACION	6.5;	2.52	2.6	52.	19.	1.63	€0.84	0.75	0.45	2.20	\$.13	0.02	0.22	C.C2	s.c.		

TANTEON CERAMICS

3. RESULT AND DISCUSSION

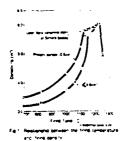
3.1 Agglomerates and Firing Density

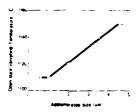
Result are shown in Fig. 1.

The increase in the density of BaTiO3 which are pulverized into primary particles at between 1120 - 1200°C is very slowly. In the case of BaTiO3 when agglomerates size is large, the increase in this density is comparatively large. The large agglomerates size is, the larger this tendensy of increasing in the density is.

3.2 Agglomerates Size and Open Pore Vanishing Temperature

Result are shown in Fig. 2. As shown in Fig. 2, the smaller the agglomates size is, the lower the firing temperature is.





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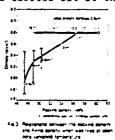
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Fig.2 Relationship between the poen para vanishing temperature of sintered body and elegionerates size of BaT-O

3.3 Effect of Packing Density and Agglomerates Size on the Firing Density Result are shown in Fig. 3.

Sintering density of the BaTiO₃ is decided not by packing density but by the agglomerates size of powder in the green sheets. Possible reasons for this is that the extra vaids are made because agglomerated particles are disturbed in the arrangement condition of powder by steric hindrance and further pores are made in the sintered body because sintering progresses with closed voids left in agglomerated particles.

Fig. 4 shown the relationship between the agglomates size and the density of the sintered body which are fired a open porse vanished temperature. The density of a sintered body increases rapidly when agglomarated particles are pulverized in to small agglomarates size, and at the primary particle diameter, saturation is carried out at the Maximum value 5.8 g/cm³.



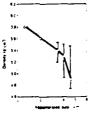


Fig. 4. Assistantiful between the septementality size and fring penalty when was fired at open sore varieties settlementure.

4. CONCLUSION

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- 1. Sinterability is improved lowering the open pores vanishing temperature when agglomerates size diminishes.
- 2. When agglomerated particles are pulverized into parimary particles, the firing density of BaTiO $_3$ at the open pore vanishing temperature becomes a fixed value of 5.8 g/cm 2 .
- 3. This value does not change at all even when the amount of binder in the green sheets is varied and the packing density is changed within the range of $49 \times 60.4\%$. The reason for this considered is that the sinterability becomes the same because the packing density becomes the same value 60.4% after debinding.
- 4. The firing density changes greatly depending on agglomerates size rather than the packing density. For instance, it becomes 4.9 g/cm 3 when the agglomerates size of BaTiO $_3$ is 4.6.m. This value becomes 5.4 g/cm 3 at 3.5.m and 5.6 g/cm 3 at 2.m.

Possible reasons for this is: numerous pores are made within the sintered body because agglomerates size is disturbed in the backing arrangement due to Steric hindrance making extra voids between agglomerated particles and further sintering progresses with closed voids left within the agglomerated particles.

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AN INVESTIGATION OF THE LOW VOLTAGE FAILURE MECHANISM* IN MULTILAYER CERAMIC CAPACITORS

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ABSTRACT: Increased leakage current was induced into multilayer ceramic capacitors by the introduction of cracks reaching from the surface through the electrode layers by means of thermal shock and then exposing the capacitors to a low voltage bias and a humid atmosphere. Results indicated that electrolytic conduction may be responsible for the increased conduction and that the proposed dendritic growth mechanisms may be more complex than necessary.

1. INTRODUCTION

In recent years a problem has been identified which concerns the insulation resistance failure of ceramic capacitors which are biased well below their rated voltages. This is a significant problem, and a research effort has focused on determining the cause of low voltage failures as well as developing a testing procedure to effectively detect those capacitors that might be prone to low voltage failures. It is a generally recognized among observers of low voltage failure that failure tends to occur only in the presence of moisture and most often in capacitors having such structural defects as voids, delaminations, or cracks extending from the surface through the electrode layers.

The dominant theory of low voltage failure in ceramic capacitors involves the growth of a dendrite of electrode material that connects two electrode layers and thus produces a short in the capacitor. According to this theory, the electrode material is dissolved in the water that condenses in the present defects which allows the dendrite to grow along the defect connecting two electrode layers. The conducting dendrite grows either by electroconduction or by precipitation. This kind of low voltage failure may be cleared by the application of a voltage high enough to vaporize the dendrite. This study reports on the interrelationship between cracks, moisture, temperature and applied voltage on the low voltage failure of multilayer ceramic capacitors.

2. EXPERIMENTAL

2.1. Materials

Special X7R, multilayer capacitors were prepared by Presidio Components, Inc., San Diego, California. The capacitors consisted of two Pd electroded 0.003 cm dielectric layers which were buried 0.0076 cm from each surface

^{*}Study sponsored by the Office of Naval Research

and separated by 0.088 cm. The separation of the layers enabled cracks to be introduced from the surface through an electrode pair without structurally damaging the capacitor.

2.1. Measurements

To insure their integrity, the entire lot, 128 units, was subjected to the methanol test. 2

Structural defects in the form of cracks were introduced into one half of the capacitors by thermal shocking. Trial and error experimentation revealed that a temperature gradient of approximately 770°C would introduce cracks extending from the surface of the capacitor through the electrode layers without otherwise damaging the properties of the capacitor.

The cracked and reference capacitors were subjected to a variation of the standard 85/85 test in which the atmosphere was allowed to be either dry or to contain 85% RH, usually in a 4 hours dry, 4 hours wet, and 4 hours dry pattern. Voltages were applied to the capacitors (0.5 to 70 VDC) and the leakage current monitored for times up to 20 days at temperatures ranging from 85 to 115°C.

3. RESULTS

In almost all cases in which low voltage failure occurred, a "sawtooth" pattern of failure was observed. With a dry atmosphere, and 1.5 VDC current density would typically hold steady at approximately 10⁻¹¹ amps/cm². When a 85% RH atmosphere was introduced, the leakage current would typically smoothly rise about 2 orders of magnitude and begin to level off at a current "plateau". The leakage current would then abruptly jump anywhere from 1 to 6 orders of magnitude and then smoothly decrease to the "plateau" level. The current level would then abruptly jump again, thus repeating the cycle until the moisture was removed from the atmosphere. The period of this cycle was usually seen to be between 20 and 45 minutes.

Low voltage failure was found to be dependent upon the voltage level on the capacitor. When a bias of 0.5 volts was introduced, no difference was observed between the leakage current of the cracked and the reference, uncracked specimen. However, at a bias from 1.0 to 20 VDC low voltage failure clearly occurred with the same "sawtooth" behavior as previously observed.

Lifetests were extended to up to 20 days with no change in the "sawtooth" pattern which was observed at 85% RH and 85°C. During these tests when the moisture was removed all of the failing capacitors showed a slow decrease of the leakage currents until they matched the reference capacitors. In a series of tests temperature was varied. The leakage current was low in the dry 85°C atmosphere, and increased dramatically when the humidity was raised. When, with the humidity still at 85% RH, the temperature was raised to 115°C, the leakage current returned to it original, lower level and the "sawtooth" pattern could no longer be observed. This supports the idea that water which condenses into the cracks in the capacitor plays the dominant role in low-voltage breakdown.

4. DISCUSSION

The low voltage current induced in the capacitors of this study exhibits the "classical" low voltage failure characteristics, i.e. the presence of

structural defects in the capacitors and the ability of high voltages to "clear" shorts in the capacitors. The "sawtooth" pattern of failure is peculiar to this study, although this behavior has been seen in porous disc capacitors exposed to similar voltages and humid atmospheres. 3)

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The "sawtooth" behavior and the absence of excess electrode material being found anywhere in the cracks suggests that dendrites are not responsible for the failure. Breakdown ceased immediately after the moisture was removed from the atmosphere which suggests that dendrites cannot be the source of the increased leakage current. Even if dendrites require water to grow in the defects, once grown they should continue to exist and facilitate breakdown.

It is much more likely that ionic conduction causes the increased leakage current. If electrolytic impurities such as chlorine or bromine salts were present conduction between the electrode layers could have occurred by means of electrolytic solution. Any soluble impurity ions could conceivably take part in this mechanism. Also, water undergoes dissociation to H⁺ and OH⁻ at 0.87 volts, which could increase conductivity. The fact that the onset of the "sawtooth" behavior occurs at voltages greater than 0.5 VDC supports this suggestion. At higher voltages the increased currents could generate enough localized heat to facilitate the evaporation of the aqueous conductor. This could also account for the "sawtooth effect" with the rapid rise in current producing enough heat to effectively halt itself.

Electrolytic conduction is a much simpler breakdown mechanism than dendritic growth, and does not require as narrow a range of conditions in order to take place. Furthermore, conditions postulated to be necessary for dendritic growth, such as the presence of moisture in existing defects and the presence of Cl ions, are ideally suited for the facilitation of an electrolytic solution as the conduction mechanism.

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Third US-Japan Seminar on Dielectric and Piezoelectric Materials

Additive Effects on Microstructure and Properties of ${\rm BaTiO}_3$ R.C. Buchanan

University of Illinois at Urbana-Champaign

Abstract

Sintered ${\rm ZrO_2}$ doped ${\rm BaTiO_3}$ compacts were prepared with and without flux addition (S2 wt1) from the CaO.Al $_2$ O $_3$.B $_2$ O $_3$ system. In ZrO $_2$ doped samples ((1.0 wt% $\rm ZrO_2$) solid solubility was found to be significantly reduced when ${\rm BaTiO_2}$ was densified (>93% ThD) at temperatures \$1300°C. The added oxide was found to exist as a grain boundary phase, which constrained discontinuous grain growth, giving a uniform fine-grained microstructure. and an essentially flat dielectric constant/ temperature profile and low dissipation factor ((1%.) over the temperature range -30 to = 110°C. As the sintering temperature was increased by steps from 1300 to 1350°C/1-2h soak, STEM EDS measurements showed a progressive Zr flux towards the grain centers and apparent counter migration of Ti ions, resulting in increased grain size and reappearance of the sharply peaked dielectric constant profile at the Curie temperature. Effectiveness of the peak suppression depended on the type of ${\rm ZrO}_2$ used. With Ca-stabilized ${\rm ZrO}_2$ additions, greater densification was achieved at equivalent temperatures, and some $\ensuremath{\mathsf{PTC}}$ effect was noted with Yttria stabilized, compared to the unstabilized ZrO, additions.

In fluxed samples near theoretical densities where achieved at temperatures (1175°C. Microstructural analysis showed nearly uniform grain sizes ((lum) and properties consistent with unfluxed ${\rm BaTiO}_3$. X-ray analysis of both fluxed and unfluxed ${\rm BaTiO}_3$ showed a decrease in the axial ratio with increasing ${\rm ZrO}_2$ content up to 2.0 wt%, with the ${\rm BaTiO}_3$ becoming

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progressively more pseudo-cubic in structure. Accompanying the decrease in tetragonality was a lower dissipation factor and an increase in the dielectric constant. No significant ion flux across the grain boundaries was noted for these samples, attributed to the relatively low sintering temperature.

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Dielectric behavior of the ${\rm ZrO}_2$ doped and fluxed samples suggested the existence of a low dielectric constant boundary phase which constrained grain development, resulting in an expected preponderance of 90° domains adjacent to the grain boundary regions. Increased dielectric constant (small grain size), suppression of polarization response at ${\rm T_c}$ (lattice strain), low dissipation factor (small grain size, second phase) and low aging rate would be the expected result. Data on microstructure, and grain boundary structure and lattice parameter changes support these observations.

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THE CONSTRUCTION OF THE PROPERTY OF THE PROPER

BARIUM TITANATE-BASED DIELECTRIC FOR MLC'S WITH HIGH K AND LOW FIRING TEMPERATURE

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ABSTRACT: A barium titanate-based dielectric has been developed which combines high volumetric efficiency, high reliability and low electrode cost. The dielectric has been formulated with controlled A/B site cation stoichiometry, a balance of donor and acceptor dopants, and a small amount (<1.5 wt%) of a specially prepared flux. The material is intended for 25U/Y5U applications at thicknesses <25 microns and has a dielectric constant at 25°C of 9000-10,000 together with low aging rate and low losses. Silver electrodes containing <30% Pd can be used. Results of life-tests and fracture toughness measurements indicate the suitability of this dielectric for applications demanding high reliability.

1. INTRODUCTION

At the present time, a variety of techniques exist for making multilayer ceramic capacitors with high volumetric efficiency and low electrode cost; these include lead injection, nickel electrodes, and the use of lead-based relaxor systems. Much of the motivation for developing these technologies has resulted from the fact that dielectrics based on barium titanate, which were compatible with low-cost high silver content electrodes, had relatively low dielectric constant. The low dielectric constant is a consequence of the addition of glass or flux to the barium titanate to reduce its sintering temperature below the melting point of silver-palladium alloys. Substantial decrease in dielectric constant can result from dilution of the high K phase, or by unwanted chemical interaction between the glass or flux and the barium titanate. These problems have been avoided in a new barium titanate-based dielectric, known as XL103.

2. EXPERIMENTAL

Submicron barium titanate was blended with additives to shift the Curie temperature to $15\text{--}20^{\circ}\text{C}$, and to broaden the Curie peak to fit 25U/Y5U temperature limits (e.g. a change in K <56% between 25 and 85°C). The composition contained a relatively small amount of lead and this was fully reacted so that it was retained completely in the ceramic during processing. No bismuth or cadmium compounds were used. A minimum of glass-forming oxides (silica, boron oxide etc.), and no fluorides, were added to aid sintering. The A/B site stoichiometry was carefully adjusted by considering the composition of the ceramic and flux as a whole; this minimized unwanted minor phases and controlled grain development.

The composition was designed for use with Du Pont 5200 binder solution to make tape (following the manufacturer's instructions) and 70% Ag/30% Pd electrodes (Du Pont 4772D). Organic binders were thoroughly removed by bakeout to 400° C, or bisque firing at 750° C. MLC's were fired on setters or in saggers at 1100° C for about 2 hours.

3. RESULTS

Typical results for MLC's of different styles are given in Table 1. Dielectric constant was 9300 to 10,000 with low DF at 1 volt/mil. TCC is tight at 85°C but K 10,000 is possible with 25U or Y5U characteristics with careful processing, as illustrated in Fig. 1. A low aging rate of 3.0% per decade and low DF at ambient temperature and above result from operation on the paraelectric side of the Curie peak. As can be seen from Fig. 2, DF does not increase with frequency (in contrast, for example, to most relaxor dielectrics that are used for high K applications).

Finally, all the test data indicate that this is a very reliable dielectric. The material has a fracture toughness of 0.9 MPa.m $^{1/2}$, typical of dielectrics based on barium titanate, and has survived various DC bias and humidity/bias tests as summarized in Table 2.

4. CONCLUSION

Low-firing dielectrics based on barium titanate are safe and easy to process, and have an established reputation for reliability. Competitive K's for 25U or Y5U applications are now possible.

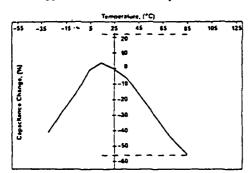
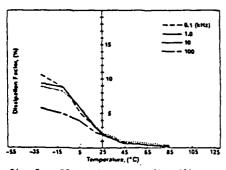


Fig. 1. TCC of XL103 (K = $10,000 \pm 500$)

ABLE 1.	Electric	al Prop	erties o	f XL1	03 ——
Firing Temp. (°C)		1 VRMS	∆C@85°C (%)	AxC	AxC
(0.5 µF 22	25 Size S A	ctive Laye	ers)		
1100	10,000	1.00%	-61.9	11500	2100
1050	9,700	1.20%	-55.9	10900	2000
(0.17 µF 12	09 Size 10	Active La	yers)		
1100	10,000	1.30%	-56.9	10000	1000
1080	9,300	1.40%	-54.5	10000	100



X

Fig. 2. DF vs. Frequency (1V/mil)

TABLE 2. MLC Life-Test Performance (25 um layers)

Volts	Temp.(°C)	Time (h)	Result
100	85	1000	No degradation
200	125	24	No degradation
50	85/85 R.H.	1000	No degradation

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ELECTRICAL CONDUCTION IN Batio, -BASED CERAMIC

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AdSTRACT: The physics of electron conduction in $BaTiO_3$ -based ceramic is reviewed. Measurements related to a conductivity anomaly near the Curie temperature for high resistance $BaTiO_3$ ceramic are presented. Contributions of donor ionization energy, crystallographic transition, and grain boundary barrier are discussed.

1. INTRODUCTION

We have established, for some specific types of ${\rm BaTi0}_3$ -based ceramic, that current is caused by electrons, with a near-exponential time increase that can be attributed to ionic movement and/or grain boundary impedance reduction. (1) The contribution of grain boundaries to impedance of high resistance ${\rm BaTi0}_3$ -based ceramic (> ${\rm 10}^{13}$ ohm-cm) is, however, still not clear. This study is intended to help clarify this issue.

2. EXPERIMENTAL

Galvanic, thermoelectric and leakage current measurement techniques we have used on $\mathrm{BaTi0}_3$ -based samples are described in the literature. (2,3) These measurements were performed mostly at elevated temperatures. In an effort to improve understanding of conduction in high resistance ceramic near room temperature, we have extended dielectric constant and conductivity measurements to below $70^{\circ}\mathrm{C}$. Samples are $\mathrm{BaTi0}_3$ -based discs with guard ring electrodes, measured under low voltage (ohmic) bias.

3. RESULTS AND DISCUSSION

Galvanic, thermoelectric and current measurements versus temperature, voltage and time have been reported elsewhere. (1-3) Some of these results will be presented.

A conductivity versus inverse temperature plot for a high resistance ${\tt BaTiO}_3$ ceramic disc is shown in Figure 1. This characteristic has at least two salient features: a) linear regions below and above the Curie temperature, with activation energies of about 0.66eV and 1.11eV respectively; b) a striking discontinuity near the Curie temperature. Such features do not resemble those of PTC or low resistance single crystal material. A somewhat similar spike (although much less prominent) has been reported for single crystal BaTiO $_3$, (4) and for polycrystalline material. (5) although those curves differ from that of Fig. 1 in other ways.

The causes of the conductivity peak have not been conclusively established. Since such a peak has been reported for single crystal material, it may not be totally a grain boundary effect for our case. However, the size of the peak in Figure 1 coincides with the large increase in permittivity, and a decrease in grain boundary barrier height would be expected. Another

possible mechanism is a reduction in conduction electron ionization energy, since such energies in general vary inversely with permittivity. More extensive measurements on polycrystalline samples, with varying grain size for example, will be necessary to clarify these points.

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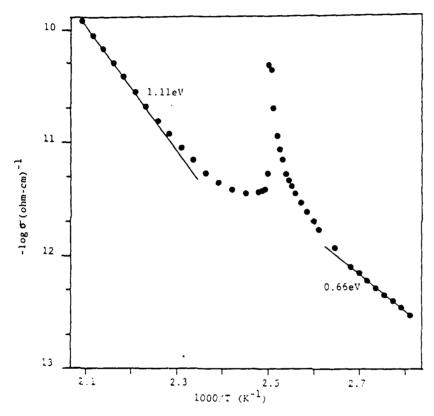


Figure 1. Electrical conductivity versus inverse temperature for BaTiO₃ ceramic disc. Conductivity spike occurs at Curie³ temperature.

DIELECTRIC AND PIEZOELECTRIC CERAMICS HISTORICAL DEVELOPMENTS: CURRENT STATUS AND FUTURE PROSPECTS

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AbSTRACT: The present generation of dielectric and piezoelectric ceramics which are used in capacitors, transducers, actuators, and PTC thermistors draw heavily upon the phenomena of ferroelectricity and ferroelasticity. In this talk, the evolution in understanding of these phenomena will be traced and the ongoing interplay between basic understanding and 'serendipitous' technological innovation underscored.

The historical groundwork for the discovery of ferroelectricity was laid in the last century by famous crystal physicists Weiss, Pasteur, Porkels, Hooke, Groth, Voigt and the brothers Curie were major contributors. Beginning with the pioneer work upon Rochelle salt and KDP, the study of ferroelectricity accelerated rapidly during World War II with the smultaneous discovery of barium titanate in the U.S., Japan and the Soviet Union. There followed in the 1950's and early 60's a period of very rapid proliferation with more than 100 new ferroelectrics identified. Over this period, many Japanese scientists made major contributions both in Japan and to groups in the USA. In the following decade, the concepts of soft modes and order parameters lead to the age of "high science" in the sixties. Heutron experiments soon authenticated the soft mode concept and lead to the discovery of a number of peculiar improper ferroelectrics such as gadolinium molybdate. It was at this time that Aizu in Japan and Shuvalov in the USSR, using symmetry arguments, began to point up the possibilities of ferroelastic and of secondary ferroic phenomena.

In the seventies came the age of diversification in which the electrotic properties, defect chemistry and transport behavior in polycrystal ceramics were more fully explored, but much theoretical work diverged strongly from practical objectives following the fascinating structures with incommensurate phases, lock in transitions, improper, pseudo proper and coupled phase changes.

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In the decade of the 80's, however, one discerns a convergence again between practical and theoretical with renewed focus upon "glassy ferroelectrics," 'ferroelectric relaxors' and other nanocomposite systems. Hew needs for very tough ceramics are driving more practical interest in ferroelastics and improper ferroelectrics, and renewed interest in the physics of martensitic metals begins to draw upon the lattice dynamic and phenomenological tools of the ferroelectrician.

For the technological thrusts in this decade, we are witnessing the beginnings of electroceramic integration, ferroelectric capacitors and piezoelectrics being integrated into multilayer ceramic packages along with metal interconnect circuitry and ceramic resistors. Following the trends clearly evident in semiconductors, we may look forward to further integration and miniaturization in the years ahead as the sophistication of new processing methods becomes more fully applied.

M-15

OPERATIONALLY INDUCED THERMAL STRESS GRADIENTS IN MILITIALS CAPACITOR

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1. INTRODUCTION

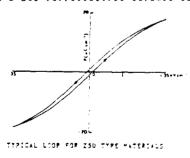
High permittivity multilayer capacitors are widely used in electronic figital and analog circuit designs. These ceramic capacitors are the engineering choice for many applications because of their compact size and low loss factors at high

The ceramics used to manufacture multilaver capacitors are ferroelectric materials. Ferroelectrics are unique in that they have a spontaneous polarization that can be reversed or reoriented. It is this unique property of polarization reversal that gives ferroelectric ceramic materials the high permittivity properties that make them desirable.

2. HYSTERETIC HEATING

In addition to contributing to the permittivity, domain reversal also contributes to the dielectric losses. The hysteretic losses per cycle are equal to the area enclosed in the polarization/field or charge/voltage hysteresis loop. The result of the hyptorisis effects is a self-herring resenses. typical example of a dielectric hysteresis loop is shown in Figure 1. These data were obtained using a computer controlled test apparatus that performed the function of the Sawyer-Tower Circuit but allowed for precise quantitative data interpretation.

The hysteretic heating and dielectric saturation effects are directly proportional to the magnitude of the spontaneous polarization. Thus, the Curie temperature acts as an upper limit on the heating effects produced by dielectric hysteresis. Figure 2 snows the temperature dependence of dielectric hysteresis in a Z5U ferroelectric ceramic capacitor.



EFFECTIVE DISSIPATION FACTOR

Deff - Va/Vs Energy lost/cycle - sres of hysteresis loop Energy stored/cycle = Q = Y = max

Figure 1

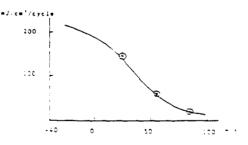


Figure 2

TEMPERATURE DEPENDENCE o f MYSTERETIC LOSSES

DIG TYPE TB# C#1(Ts Ze O; CUPIE TEMPERATURE - 4010

3. THERMAL STRESS GRADIENTS IN MULTILAYER CAPACITORS

when an alternating voltage is applied to a high dielectric constant, multilayer ceramic chip capacitor, the component will self-heat due to the hysteretic effects intrinsic to the ferroelectric nature of the material. The high temperature itself is not intrinsically harmful to the ceramic capacitor. However, due to the manner in which multilayer capacitors are manufactured, the heat is not uniformly distributed in the capacitor. The hysteretic heating effects only occur in the ceramic material that is between two electrode layers. This leaves a dead zone near the end terminations that has no electric field and therefore, no dielectric heating (Fig 3). The result of this situation is to set up a thermal gradient that couples through thermal expansion to set up a stress gradient in the ceramic.

4. CALCULATED HEATING RATE AND STRESSES

Using the temperature dependent dielectric heating data shown in Figure 2. It is possible to make an approximate calculation of the heating rate for a multilayer chip capacitor using operating voltages seen in typical circuit applications. The calculations use the thermal properties of barium titunate and the dimensions of a typical chip capacitor. Using these data we can calculate the chip heating rate that occurs when the circuit starts operation from a cold ambient condition. The heat input, Q, is given by:

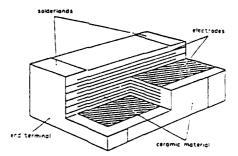
$$0 = U_d \times \text{volume}$$

where $^{ij}_{\ d}$ is the energy per unit volume dissipated on each cycle of the circuit voltage. The temperature rise, dT, is given by:

where $\mathbf{C}_{\mathbf{v}}$ is the volume specific heat. For the test conditions of:

volume =
$$5.2 \times 10^{-3}$$
cc

$$C_{..} = 3.0 \text{ J/°C-cc}$$



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Figure 3

we find that dT = 0.055°C/cycle. If the circuit is operating at a 1 kHz frequency, and we assume that heat cannot be quickly lost to the outside, the heating rate can approach 55°C/sec.

The highest stress condition for multilayer capacitors may occur during circuit start-up conditions at ambient temperatures. In fact, a collect ambient will produce higher stresses. An CLC with a 120° C gradient from hysteretic heating can attain a peak stress of $460~{\rm Kg}\,{\rm m}^{2}$, and the ALC can reach this level in less than $10~{\rm seconds}$.

MICROSTRUCTURES AND NANOSTRUCTURES OF RELAXOR FERROELECTRICS

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ABSTRACT: In order to better understand and exploit the properties of relaxor ferroelectrics it is imperative to develop a deeper understanding of the microstructure and microchemistry of these materials. Since many fundamental properties of relaxors have been traced to events taking place on a nonoscopic scale, analytical and transmission electron microscopy (AEM and TEM) are ideal techniques for investigating these materials further. The present work describes the results of detailed TEM and AEM studies of several important classes of lead-based relaxor ferroelectric systems.

1. LEAD SCANDIUM TANTALATE Pb(Sc_{1/2}Ta_{1/2})0₃

Lead scandium tantalate (PST) is an attractive model system in which to study relaxor behavior because of the degree of control over the B-site cation ordering that can be achieved by heat treatment. Setter and $Cross^{1}$ have studied extensively the dielectric properties of PST as a function of the degree of ordering (S) of the Sc^{3+} and Nb^{5+} ions. In our work on PST we have studied the microstructure as a function of the degree of cation ordering Sc^{2} . Single crystals of ordered (S=0.8) and disordered (S=0.35) PST were found to contain ordered microchemical domains Sc^{2} 20-60 nm in size dispersed within a disordered matrix Nc^{2} . No microstructural changes were observed after the single crystals were annealed for 24 hr at 1000°C. In sintered polycrystals aged similarly, however, the domains did coarsen considerably producing non-uniform structures containing anti-phase domain boundaries (APB's) separating domains which varied in size from Nc^{2} 20-400nm. Anomolous (1/2,1/2,0) superlattice reflections were observed in the selected area diffraction (SAD) patterns in all samples. This reflection is forbidden for a perfect NaCl-type ordered structure. It was postulated that these anomolous reflections criginated from small regions (Nc^{2} 1nm) of short range order having a primative type of unit cell.

2. LEAD MAGNESIUM HIOBATE $Pb(Mg_{1/3}Nb_{2/3})0_3$

Microchemical ordering, ferroelectric domains and secondary phases have been characterized in Pb(Mg $_{1/3}$ Nb $_{2/3}$) $_{3}$ (PMN) and PMN:10 \mathbb{Z} PbTiO $_{3}^{-3}$). A substantial degree of ordering between the Mg $_{2}^{-4}$ and Nb $_{2}^{-4}$ ions in single crystal and polycrystalline PMN and PMN:PT was revealed by the presence of (1/2,1/2,1/2) superlattice reflections in the SAD patterns. Dark field imaging using the (1/2,1/2,1/2) reflection provided direct evidence of microchemical ordering on a scale of \approx 2-5nm. One interpretation of the SAD patterns is that the Mg $_{2}^{-4}$ and Nb $_{2}^{-4}$ ions order, on a nanostructural scale, in the same manner that Sc $_{2}^{-4}$ and Ta $_{2}^{-4}$ order in PST. A NaCl-type ordering arrangement in PMN, however, would upset the local stoichiometry and introduce a charge inbalance that would, as a consequence, be expected to limit the domains to very small sizes. A hint that this may indeed be the case comes from observations that the domains in PMN do strongly resist coarsening during prolonged neat treatments. Alternatively, the ordering could take place as alternating (111) layers with Nb $_{2}^{-4}$ ions in one layer and a mixture of Nb $_{2}^{-4}$ ions in the other. Microchemical analysis is required to distinguish between these models.

Ferroelectric domains were observed only in PMN containing 10° PbTiO $_3$ and only at temperatures less than -120°C. The domain boundaries were found to lie on (100) and (110) which is consistent with the formation of 70° and 109° domain boundaries in the rhombohedral system. The angle x in the rhombohedral unit cell was determined to be 89.95° $x = 90^\circ$.

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A cubic pyrochlore phase in the form of large isolated grains of composition $^{\text{Pb}}2^{\text{Nb}}1.75^{\text{Mg}}0.25^{0}6.62$ was detected in sintered samples made via the mixed oxide method. Samples made from reagent grade starting oxides contained second phase films over a significant proportion of the grain boundaries. The films were rich in lead and phosphorus. The use of ultra high purity starting powders minimized the amount of intergranular impurity phase present, leading to much improved dielectric properties.

3. LEAD LANTHANUM MAGNESIUM HIOBATE $Pb_{1-x}La_x^{Mg}(1+x)/3^{Nb}(2-x)/3^03$

A family of compositions referred to as PLMN were studied in which 110:Nb was adjusted closer to 1:1 in order to enhance the degree of 110 mere studied in which 110:Nb was adjusted closer to 1:1 in order to enhance the degree of 110 mere studied; on the Pb $^{2+}$ sites. The following range of compositions were studied: 110:0.01 km < 0.5. For 110:0.05 isolated microchemical domains 110:10 mm in size were observed. For 110:0.1 complete ordering was observed along with the appearance of APB's. The microdomain size increased with increasing 110:10 mere observed. Strong (1/2.1/2.1/2) superlattice reflections were observed in the x-ray diffraction patterns as well as in the SAD patterns. Evidence for a ferroelectric domain structure at 110:180°C was obtained.

4. LEAD ZINC NIOBATE: LEAD TITANATE Pb(Zn1/3Nb2/3)03:10% PbTiO3

Flux grown single crystals of PZN:10%PT were studied by TEM; this composition falls on the tetragonal:rhombohedral norphotropic chase boundary at room temperature. The material was confirmed to be perovskite by SAD. Very faint (1/2,1/2,1/2) superlattice reflections were observed in the SAD patterns indicating a slight tendency for ordering (much less than in PMR however).

Ferroelectric domains were visible at room temperature and below. The domain width was very small (<10nm) and the domain configurations were consistent with rhombohedral symmetry.

ACICIONLEDGENERTS

The author gratefully acknowledges valuable colluboration with H.M. Chan, J. Chen, A. Gorton, D.M. Smyth, L.E. Cross and A. Bhalla as well as the financial support of the Naterials Research Division of the National Science Foundation and the E.I. DuPont de Nemours Company.

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DIELECTRIC PROPERTIES OF FINE-GRAINED Batio $_3$ CERAMICS DERIVED FROM Batio (C₂O₄) $_2$ · 4H₂O

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ABSTRACT: FINE-GRAINED BaTiO $_3$ powder was produced by coprecipitation method using oxalic acid. The effect of BaO/TiO $_2$ mole ratio and sintering parameters on the dielectric properties of the products were studied. At the BaO/TiO $_2$ mole ratio = 1.000, dielectric constant value at room temperature (K25) and at curie temperature (K125) were 6500 and 14000 respectively.

1. INTRODUCTION

The process of manufacturing ${\rm BaTiO_3}$ powder which is used as a raw material of capacitors include both solid phase reaction and reaction in solution. ${\rm BaTiO(C_2O_4)_2}, {\rm 4H_2O}$ was initially prepared by reaction in solution from ${\rm TiCl_4}, {\rm BaCl_2}$ and ${\rm (COOH)_2}.$ The effect of ${\rm BaO/TiO_2}$ mole ratio and sintering parameters on the dielectric properties of fine-grained ${\rm BaTiO_3}$ derived from ${\rm BaTiO(C_2O_4)_2}, {\rm 4H_2O}$ were studied.

2. EXPERIMENTAL

2.1 MATERIALS

BaCl $_2$ and oxalic acid was calcined at 800 C for 1 Hr in air. Calcined BaTiO $_3$ powders were pressed into pellet at uniaxial pressures of 1000 Kg/cm 2 and sintered for 1.5 - 2.0 Hrs in air. BaO/TiO $_2$ mole ratio of BaTiO(C_2 O $_4$) $_2$ 4H $_2$ U was controlled by the mole ratio of raw materials such as TiCl $_4$ /(COOH) $_2$ and TiCl $_4$ /BaCl $_2$, method of admixing, pH of solution and so on.

2.2 MEASUREMENT

The relative dielectric constant was measured as a function of temperature at 1 kHz using a low frequency impedance analyzer Hewlett Packard 4192 A. Indiam-Garium electrode were placed on both surfaces of the samples by Painting.

3. RESULTS

 ${\sf BaTiO_3}$ powders produced in such a process were 0.2 - 0.3 μm in drameter of grain size and impurity level was less than 100 wt PPM. Effect of ${\sf BaO/TiO_2}$ mole ratio and sintering temperature on the dielectric constant, dissipation factor.

relative density, drain Size of ceramics are shown in Table 1, and 1.9.). Temperature dependence of the dielectric constant of MaTiO_3 cerumin with BaO/TiO_3 mole ratio = 1.000 is shown in Fig. 2.

TABLE 1. Effect of mole ratio and sintering temperature on the dielectric properties, density and grain size.

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BAOZTIO ₂	Sintering temp [*C]	K25	K125	tan ó ²⁵ ° (*)	5 D 1%1		a (ا سېرا ت ا سېرا ت
n 991	1250 1300	2750 2190	6120 12860	6.2	82 95		-	60 100
0.995	1250	6300	13310	5.4	94	2	-	5
1.000	1200 1250 1300	6420 6470 4660	12580 13860 13900	2.8 2.5 3.2	91 95 97	1 1 3	-	2 2 10
1.004	1200 1250	6580 6060	14416	3.7	96 93	2 2	-	4 5
1.007	1150 1200 1250	5770 4230 3890	11270 13440 13690	2.0 3.0 4.5	97 9 8 97	1 1 1	-	3 4

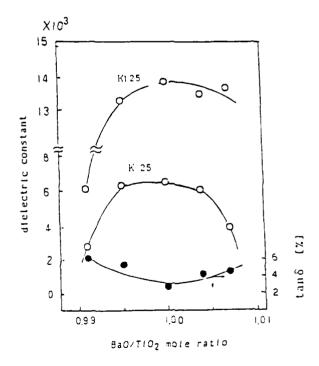


Fig. 1. Effect of BaO/TiO $_2$ mole ratio on dielectric properties at 1250 $^{\circ}$ C

4. DISCUSSION

The density and microstructure of the sintered body are sconificantly influenced by the Bao-Tro_2 mole ratio. Bao/Tro_2 mole ratio above 1.0 causes lowering of sintering temperature. On the other hand, when Bao/Tro_2 mole ratio is below 1.0. It is difficult to obtain dense ceramic. This is due to the fact that raising of firing temperature causes remarkable grain growth on account of the liquid phase sintering of BaTro_3. Bao/Tro_2 mole ratio of 1.00 gives dense and fine grained ceramics. It was also found that the dielectric property was strongly effected by the Bao/Tro_2 mole ratio. Bao/Tro_2 = 1.000 + 0.005 resulted in the highest dielectric constant. When the Bao/Tro_2 mole ratio was 1.000, quite high values of dielectric constant at room temperature (K25) and at Curie temperature (K125) were obtained, that is 6500 and 14000 respectively (Fig. 2). These very high dielectric constant may be interpreted by the internal stress model reported by G. Arlt. D. Hennings et.al. (1) and authors also confirmed this.

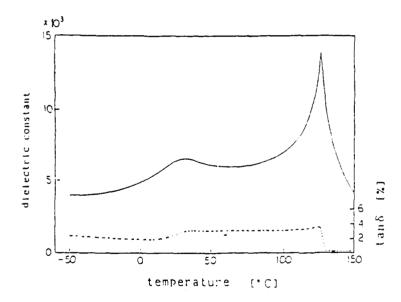


Fig. 2. Temperature dependence of the dielectric properties of BaTiO $_3$ ceramic with BaO/TiO $_2$ mole ratio = 1.000

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LOW TEMPERATURE FIRED GLASS-CERAMICS DIELECTRIC MATERIAL

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Research and Development Division, Asahi Glass Company, Yokohama, Japan.

ABSTRACT: Sintering process of glass-Al $_2$ O $_3$ -2MgO·SiO $_2$ system and glass-Al $_2$ O $_3$ system between 800°C to 900°C were investigated. At glass-Al $_2$ O $_3$ system, glass and Al $_2$ O $_3$ don't react, while, at glass-Al $_2$ O $_3$ -2MgO·SiO $_2$ system, 2MgO·SiO $_2$ dissolves in the glass and, as the result, B $_2$ O $_3$ in the glass react with Al $_2$ O $_3$, and new crystal 2Al $_2$ O $_3$ ·B $_2$ O $_3$ occurs. This process is effective for dense sintering and chemical resistance.

1. INTRODUCTION

A low temperature fired multilayer ceramic technology has been developed for hybrid circuits.

The low temperature fired ceramic is composed of glass phases and refractory filler materials. Relative amount of the glass and filler phases are adjusted to give dense, hermetic fired structures.

The present study reports the interaction between borosilicate glass and ceramics, and the effect of $2Mg0 \cdot SiO_2$ additives.

2. EXPERIMENTAL

2.1. Materials

Several kinds of glass-Al $_2$ O $_3$ and glass-Al $_2$ O $_3$ -2MgO·SiO $_2$ films were made by a doctor blade method, and sintered at 900°C for 2h in air, and boiled in 90°C hot water to test the chemical stability.

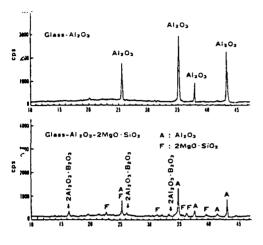
2.2. Measurements

Mechanical and electrical properties were measured. Σ -ray diffraction, Scanning Electron Microscope and Transmission Electron Microscope observations were carried out on the sintered samples which are before and after boiling.

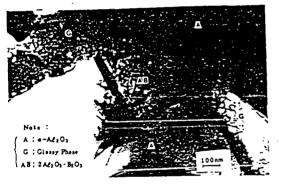
3. RESULTS and DISCUSSION

At glass-Al $_2$ O $_3$ binary system, glass and Al $_2$ O $_3$ did not react at 900°C. At glass-Al $_2$ O $_3$ -2MgO·SiO $_2$ ternary system, major part of 2MgO·SiO $_2$ dissolved in the glass and as the result, B $_2$ O $_3$ in the glass reacted with Al $_2$ O $_3$ and new needle like crystal 2Al $_2$ O $_3$ ·B $_2$ O $_3$ occured in the grain boundary of glass and Al $_2$ O $_3$. It was clarified that the process and the structure is effective for dense sintering and chemical resistance. The reasons are considered as follows:

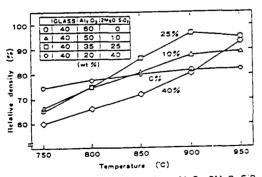
- (1) 2Al2O3·B2O3 crystallization is effective for sintering agent
- (2) Relative amount of ${\rm B}_2{\rm O}_3$ in the glass phase are reduced, which has good resistance to water.



X-ray diffraction patterns of various compositions sintered at 900°C



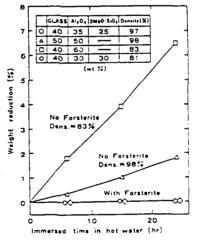
Transmission Electron Microscope Observation



Relative density of various glass-Al $_2$ O $_3$ -2MgO·SiO $_3$ compositions with temperature.

Properties

	GLASS-Al ₂ O ₃ - 2MgO·SiO ₂
Sintering Temperature (°C)	900
Flexural Strength (kg/cm²)	2000
Thermal conductivity (cal/deg-cm-sec)	0.007
Thermal Expansion Coefficient (deg-1)	60×10 ⁻⁷
Dielectric Constant (100kHz)	6.5
Dissipation Factor (100kHz)	1.5×10 ⁻³
Volume Resistivity (Ω-cm)	> 10 ¹⁴
Surface Roughness (ARa)	0.5



Corrosion resistance to hot water at 92°C (sample dimension; 17°m x17°m x5°m)

LOW TEMPERATURE FIRED MULTILAYER CERAMIC CAPACITOR WITH MI ELECTROIES

H.KISHI, T.WADA, S.MURAI, H.CHAZONO, and N.YAMAOKA Central Research Institute, Taiyo Yuden Co., LTD., Gunma, Japan

ABSTRACT: Lielectric ceramics based on varium titanate and glass components for multilayer ceramic capacitor with nickel electrodes has been developed. The ceramics could be fired at temperature less than 1200 °C in an atmosphere of low oxygen partial pressure, exhibited high dielectric constant (Y5V:10000-12000, X7R:2700-3300) and high resistivity (above 10 12 cm). The multilayer chip capacitors with nickel electrodes using these dielectic materials have good characteristics.

1. INTRODUCTION

Conventional multilayer ceramic capacitors employ electrodes of noble metals such as Pd or Ag. For replacing Pd or Ag by cheaper alternatives, multilayer ceramic capacitors with base metal electrodes have been reported. In this work, we presents the dielectric materials which can be fired at low temperature in reduced atmosphere. Then we shows their application to multilayer chip capacitors with Ni electrodes.

2. EXPERIMENTAL PROCEDURE

The starting materials for the basic perovskite compounds were BaCO $_3$, SrCC $_3$, CaCO $_3$, TiCO $_2$ and ZrO $_2$. They were weighed according to the general formula, (Ba $_{1-x-y}$ Sr $_x$ Ca $_y$)(Ti $_{1-z}$ Zr $_z$)Co $_3$ and ball-milled in water. After drying, the powder was calcined in air at 1200°C for 2 hours. The glass components (alkaline earth lithiumsilicate glass, were then added to the calcined perovskite powders. Lisk samples were formed by ordinary technique.

An In-Ga alloy electrode was then attached to the both surfaces of the sintered disk.

Multilayer chip capacitors were prepared as shown in Fig. 1. Nickel metal was used as both of internal and terminal electrodes and co-fired in the firing process of ceramic bodies. The samples were fired in a low exygen atmosphere controlled by No and Ho gasses.

Dielectric constant and dissipation factor were teasured by LOR meter at "kHz with TV rms. Insulation resistance was neasured with a night-resistance meter in one minute after applying 100VDO.

3. RESULTS and DISCUSSION

3.1 Dielectric materials

The samples with glass components assessive fires with full densification at fill to to foll to Fig.2 snows insulation resistance of the carries sinteres in an atmosphere Fig. *107 stm.

Ceramic powder	-
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Green sheet	
Electrode printing	Chin
Laminating	
<u>Cutti</u> ng	
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Fig. 1 Flore ant for matter per output patacities.

Insulation resistance increase maniedly on addition of glass compenents. The insulation resistance is higher than $10^{12} \Omega cm$.

Fig.3(a),(t) shows temperature characteristics if dielectric constant. The system of $(5a_{1-x-y}Sr_xCa_y)(Ti_{1-z}2r_z)0_3$ -glass components shows various temperature characteristics according to their compositions and exhibit high dielectric constant 10000-12000 for Y5V specification, 2700-3300 for X7R specification.

3.2 Properties of chip capacitor

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4.4.5

The characteristics for multilayer chip capacitors with nickel electrodes are shown in Table 1. The capacitors are compactly designed and have large capacitance and satisfy ELA standard specification. The multilayer chip capacitors with nickel electrodes using the dielectric materials of this system are as reliable as those with precious metal electrodes.

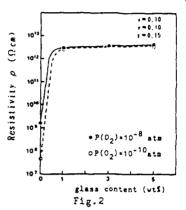
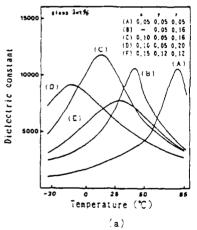


Fig. 2. Resistivity v.s. glass content.

Fig. 3 (a).(b). Temperature dependence of dielectric constant for various composition.

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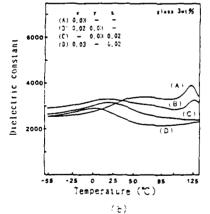


Fig.3

	٩	hip	size	(88)		dielectric characteristics			100(%)				
	L	1	Ť	t*	n = •	Cap.(nF)	D.F (%	ALR (MO)	BDV (V	¥-55℃	-30℃	85℃	1:25℃
Y 5 V	3.2	1.5	1.25	13	60	1170	2.3	2×10°	500	-	-30	-75	Ţ -
X7R	3.2	1.5	1.25	18	35	116	2 0	1×10*	-00	-: 2	- 9		- 3

* to thickness of diejectric laver (u.s.

Table 1.
Characteristics of multilayer chip capacitors with mickel

本本市、numbers of effective dielectric layer

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BARIUM TITANATE CERAMICS FOR BASE METAL MONOLITHIC CERAMIC CAPACITORS

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ABSTRACT: Barium titanate ceramics doped with SrO, CaO and ${\rm ZrO}_2$ were fired under several low oxygen partial pressures, and their dielectric properties were measured. The dielectrics yielded a high dielectric constant (k=14,000) and high resistivity (${}^{\circ}10^{12}\Omega$ -cm) when they were fired with an nickel electrode in a reducing atmosphere of ${10}^{-13}{}^{\circ}{\rm P(O_2)}{}^{\circ}10^{-11}{}^{\rm MPa}$. The dielectrics are suitable for large-capacitance monolithic ceramic capacitors with nickel electrodes.

1. INTRODUCTION

Advanced dielectrics and firing technologies for monolithic ceramic capacitors have been developed in order to be able to substitute base metals, such as Ni, for noble metal electrodes $^{1-4}$. In this case, the firing of the capacitors should be carried out under low oxygen atmosphere, since nickel electrodes oxidize completely when fired in air. In this study, newly developed dielectrics were fired under several $P(\mathcal{O}_2)$ atmospheres in order to realize practical firing conditions of nickel electrode monolithic capacitors.

2. EXPERIMENTAL

2.1. Materials

Two dielectric materials "A" and "B" were prepared by the conventional powder process. "A" is a new composition and "B" is a normal one.

A: $[(Ba_{0.82}Sr_{0.08}Ca_{0.10})O]_{1.005}[(Ti_{0.82}Zr_{0.18})O_2]+0.lat%MnO_2]$

B: Ba(Ti_{0.82}Zr_{0.12})O₃

The test samples were prepared in disc form (14 mm in diameter by 1.0 mm thick). The discs, with and without Ni-paste on the surface, were sintered under $P(O_2)$ ranges of 10^{-2} to $10^{-16} \mathrm{MPa}$.

2.2. Measurements

An Ir-Ga alloy was applied as a conducting electrode on the sintered disc. Resistance was measured at room temperature on a megohnmeter at 500~V dc or on a resistance meter with low voltage. Capacitance was measured on an LF impedance analyzer at 1~V and 1~kHz.

3. RESULTS

Figure 1 shows the resistivity at room temperature vs sintering $P(O_2)$. The "A" dielectrics yielded high resistivity ($>10^{12}\Omega$ -cm), when $P(O_2)$ was higher than $3\times10^{-13} MPa$. At $P(O_2)$ lower than $10^{-14} MPa$, the samples were converted to dark-colored semiconductors. This marginal $P(O_2)$ was close to the equilibrium one for Ti_2O_3 - TiO_2 (e.g., $5\times10^{-14} MPa$ at $1300\,^{\circ}C$). The dielectrics "B" always showed low resistivity.

Figure 2 shows the dependence of the dielectric constant on the sintering atmosphere. The "A" dielectrics sintered in the $P(C_n)$ range of 10^{-13} to

 $10^{-11} \rm Mpa$ showed a very high dielectric constant (14,000) and low dissipation factor (-1.5%). At the P(O_2) regions higher than $10^{-11} \rm Mpa$, the dielectric constant of the Ni-electroded disc decreased with increasing P(O_2). The dependence of the dielectric constant on temperature for the "A" dielectrics co-fired with the nickel electrode in various P(O_2) atmospheres is shown in Fig. 3. The temperature which shows maximum dielectric constant was not affected by the sintering atmosphere.

4. DISCUSSION

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The equilibrium $P(O_2)$ for Ni-NiO at $1300\,^{\circ}\text{C}$ is $2\text{xl}0^{-8}\text{MPa}$. But even in the lower $P(O_2)$ regions (to 10^{-11}MPa), nickel metal on the dielectric ceramics was partially oxidized and reacted with ceramics, resulting in a degradation of the dielectric properties. Firing atmosphere for the nickel-electrode monolithic ceramic capacitors with "A" dielectrics has to be controlled accurately within the $P(O_2)$ ranges of 10^{-11} to 10^{-13}MPa .

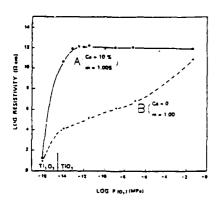


Fig. 1. Resistivity of the "A" and "B" dielectrics sintered under various P(O₂) at 1300°C and 1400°C, respectively, for 2 h.

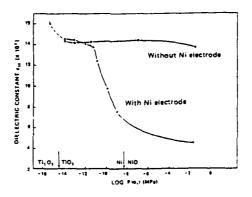


Fig. 2. Dielectric constant of the "A" dielectrics sintered with and without Ni-electrode under various $P(O_2)$ atmosphere at 1300 °C for 2 h.

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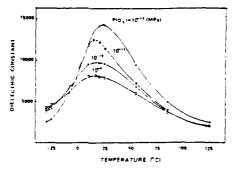


Fig. 3. Temperature dependence of dielectric constant of the "A" dielectrics sintered with Ni-electrode under low caygen partial pressures at 1300°C for 2 h.

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TEMPHRATURE STABLE PARISM TITANATE CERAMICS FOR PASE METAL MIDITILAYER CAPACITORS

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APCTRACT: In order to develop XTP multilayer ceramic capacitor with tase metal electrodes, the system of RaTi(γ -Ca2r(γ -MnC-Y2(γ) was studied. These dielectric ceramics are sintered in an atmosphere of low oxygen partial pressure to yield a high resistivity (10¹² \(\Omega\) cm), a high dielectric constant (2700-3300) and a flat dielectric temperature characteristic. The multi-layer ceramic capacitors with nickel electrodes fabricated using the dielectrics have good chracteristics that meet XTF.

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1. INTRODUCTION

Multilayer ceramic capacitors have been increasingly used in electronic circuits. However, the material costs of the capacitor are high because of precious metal electrodes such as palladium. Several methods are proposed to reduce the material costs. Cne way to achieve low cost is to use base metal such as nickel and copper for internal electrodes. The present study reports the dielectric materials that can be fired in a low oxygen atmosphere and have a flat dielectric temperature characteristic that meets X7R, and their application to multilayer ceramic capacitors with tase metal electrodes.

2. EXPERIMENTAL PHOCEDURE

2.1. Dielectric Materials

Given quantities of PaTiC₃, MaTrC₃, MaTrC₃ and Y₂C₃ were weighed, and they were mixed with 3% PVA binder and water. After drying, the powder was pressed into a disk 12 mm in diameter and 1.2 mm in thickness. The disk was baked at 500% O in air to burn out binder, then it was fired at 1270-1350% in a low oxygen atmosphere controlled by $\%_2$ and $\%_2$ gasses. An In-Ga electrode was attached to the surface of the sintered disk.

Capacitance and dissipation factor were measured by a dimital LOP meter (YHP,4274A) at 1 XHz with 1 Yrms. Thelectric constant was calculated from a capacitance and a dimension of a right. Insulation resistance was measured after applying 250 Vdc for 1 minute.

2.2. Multilayer Ceramic Capacitor

Green chips were farricated using green dielectric sheets with 35,4m thickness and a nickel electrode ink in the conventional green sheet method. These chips were fixed in a low oxygen atmosphere. The termination was formed by applying nickel alloy electrode on each end of the only and fixed at 600^{-90} in M_{\odot} .

Capacitance and dissipation factor were measured in the same way as the disk samples. Insulation resistance was measured after applying 50 Vdc for 1 minute.

3. RESULTS /TO DISCUSSION

Figure 1 and 2 snow temperature characteristics of dielectric concent as a function of $\operatorname{Ca7r(3)}$ or $\operatorname{Y}_2\operatorname{O}_3$ content. Temperature characteristic curves shift clockwise with increasing $\operatorname{Ca2r(3)}$ content, and become flat with increasing $\operatorname{Y}_2\operatorname{C}_3$ content. However, ceramics containing more than 1 mol* $\operatorname{Y}_2\operatorname{C}_3$ are not well sintered even at $\operatorname{T}_2\operatorname{CP}$ 0. The optimum contents of $\operatorname{Ca2r(3)}$ and $\operatorname{Y}_2\operatorname{C}_3$ for a flat temperature containing (within $\mathbf{x}^{(2)}$ 0.) are in the name of $\operatorname{Ca2r(3)}$ mol* $\operatorname{Ca2r(3)}$ and $\operatorname{$

Figure 3 shows dielectric constant and inculation redictance as a function of in content.

Dielectric constant decreases with increasing hmC content, but these compositions have relatively high dielectric constant (>2.7%). Insulation resistance is higher than $^{1/2}\Omega$ cm when the ceramics contain more than $^{1/2}\Omega$ cm which. The increase of insulation resistance on addition of MnC can be understood by the compensation action of the acceptor type depart.

Figure 4 shows the insulation resistance of ceramics related to the coventional $FaTiC_3 = Kb_2C_5$ system and the new developed system when they are fired in several oxygen atmospheres. Insulation resistance of the conventional system decreases remarkably with decreasing oxygen partial pressure. (In the other hand, the new developed system keepshigh insulation resistance in low oxygen partial pressure ($\frac{1}{3} \times \frac{10^{-10}}{3} = \frac{1}{3} \times \frac{10^{-5}}{3}$ atm.). In order to make a nickel electrodes multilayer ceramic capacitor, green chips should be fired under low oxygen partial pressure less than that of the Ni-NiO equilibrium at firing temperature. Since the oxygen partial pressure of the Ni-RiO equilibrium at 1350°0 is about 10^{-6} atm., the new developed ceramics are usable for this purpose.

The dielectric material of this system was applied to the multilayer ceramic capacitor with nickel electrodes. The characteristics of capacitors are listed in Table 1. These capacitors meet X7R and show no degradation under the load life test (125°C, 100 Vdc, 1000 Hr).

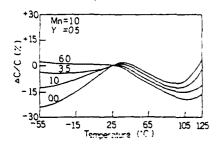


Fig. 1 TCC as a function of $Ca7xC_{\frac{\pi}{2}}$ content.

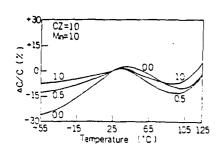


Fig. 2 TCC as a function of Y_2C_3 content.

Table 1 Characteristics of MLC with Mi electrodes.

Chip size: 3.2 x 1.6 mm

Green thickness of dielectric layer: 35 mm

CHARACTERI	STICS	PREYAGE	40LAYERS
CAPACITANO	E (nF)	53.4	110.5
J. F	(%)	2 2	2 0
IR	(GD)	2 5	: 2
CR PRODUCT	(Q.F.)	:300	1300
SDV (VDC	min.)	500	400
TCC	(EIA)	XIR	XTR

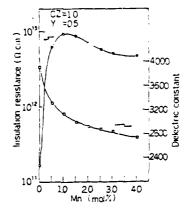


Fig. 3 IR and dielectric constant v.s MnC.

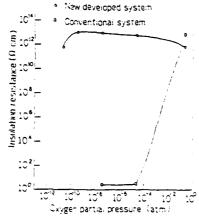


Fig. 4 IR v.s firing atmosphere (PC2).

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BARIUM MODIFIED LEAD ZINC NIOBATE DIELECTRICS FOR MULTILAYER CERAMIC CAPACITOR

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ABSTRACT: Substitution effects for lead zinc miobate based ceramic by barium and titanium have been systematically investigated. It was found that the partially substituted lead zinc miobate dielectric by barium and titanium has shown to be a promising candidate for multilayer ceramic capacitor.

1. INTRODUCTION

In order to improve disadvantages of BaT.O $_3$ based dielectric material, studies of new high dielectric constant relaxor materials are widely carried out. The authors have succeeded in easily synthesizing perovskite type lead zinc niobate as a ceramic form, by means of partial substitution by strontium and titanium $^{1-2}$. In the present study, dielectric properties of the lead zinc niobate based compositions, in which the dielectric constant maxima show around the room temperature, has been investigated by the adjustment of the amount of barium and titanium substitution.

2. EXPERIMENTAL PROCEDURE

The studied compositions were of the general formula,

 $(Pb_{1-x}Ba_x)[(2n_{1/3}Nb_{2/3})_yTi_z]0_3$ which hereafter is abbraviated as PB2T 100x/100y/100z. Dielectric powder preparation was carried out by conventional method. The disks were fired in a magnesia crucible at 980 to 1,150°C for 2 hours. Then they were formed to 1.0mm thick, printed silver paste as electrodes on both surfaces and fired at 700°C.

3. EXPERIMENTAL RESULTS

The sintered bodies were crashed into powders and measured a relative amount of perovskite phase (P.A.) by X-ray diffraction method with CuKa radiation. The results are shown in Fig. 1. It can be seen that the composition partially substituted by barium and titanium represents high (P.A.) ratio.

Figure 2 shows temperature dependences of relative dielectric constant and dissipation factor in PBZT 27/60/40 compared to Y5T characteristics BaTiO $_3$ based dielectric. In all temperature regions, the PBZT 27/60/40 shows gentle and high dielectric constant curve compared to the BaTiO $_3$ based dielectric owing to diffuse phase transition effect.

Figure 3 shows tolerance factor t in the PB2T system. It can be found that (P.A.) tends to high with increasing in substitution ratio of barium

and titanium. Furthermore, perovskite crystal structure has an ionic bond. As a scale of amount of ionic bond component, electronegativity proposed by Pauling is well known. According to this, the amount of ionic bond component between two atoms PAB are expressed as

 $P_{AB}^{=1-exp[-1/4(\chi_A-\chi_B)^2]}$.

Figure 4 shows the amount of ionic character in the PBZT system. Since the amount of ionic character becomes larger when $\boldsymbol{P}_{\boldsymbol{A}\boldsymbol{B}}$ tends to unity, it is explained that barium and titanium substitution is effective for perovskite phase formation of lead zinc niobate ceramics.

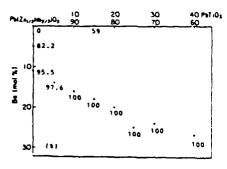
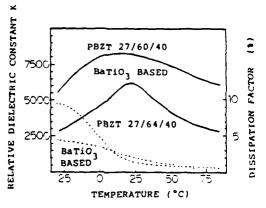


Fig. 1. Relative of amount perovskite phase for the PBZT system.



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Fig. 2. Dielectric properties for the PBZT 27/60/40 and conventional YST characteristics BaTiO₃ based dielectric.

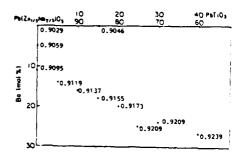


Fig. 3. Tolerance factor for PBZT system.

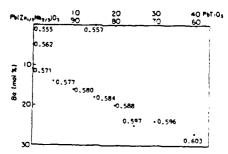


Fig. 4. Amount of ionic character for the PBZT system.

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DIELECTRIC RELAXATION STUDIES IN SOME POLYMER - P2T COMPOSITES

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Due to the rapid increase in application of ferroelectrics in electronic industry, ferroelectric titanate and niobate materials have been studied extensively [1,2] and composite materials made up of such ferroelectric particles dispersed in a polymer matrix have attracted the attention of materials technologists due to its ese of preparation, higher sensitivities and favourable ecoconomics. Anomalous piezo- / pyro- electric properties have been noticed [3] in composites, basically due to the changes in the molecular motion of the polymer. In the present study, dielectric relaxation studies were therefore planned on composites between PZT and certain mechanically sound polymeric materials to unfold the effect of composite formation on the molecular motion of the polymer phase.

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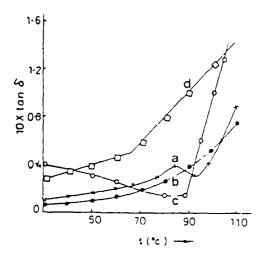
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The polymer materials used for the composite formation were vinyl acetate - vinyl chloride (VA-VC) co-polymer, amide cured epoxy (ACE), nitrile rubber - poly vinyl chloride (NR-PVC) blend and piezoelectric poly vinylidene fluoride (PVDF). The base materials for VA-VC, ACE and NR-PVC were obtained from Calico Products (Bombay). The PVDF material used was Kynar grade film as supplied by Pennwalt USA. The starting material was of pure trans form (TTTT configuration).

Free films of the composite materials were formed on a motorized film applicator between 75 micron PZT particles (composition: Pb0.94 La0.04 Zr0.57 Ti0.49 O3) 55vol% and the VA-VC, ACE and NR-PVC polymers. PZT - PVDF composite was formed by pressing a pre-formed PZT film against the Kynar PVDF film at about 60 C. The t hicknessess of the films were limited to the size of PZT particles (about 75 microns).

Dielectric measurements were performed using a Wayne-kerr autobalance capacitance bridge, in the temperature range 30 to 150 C. A silicon oil thermostat was used for the temperature variation studies.

The variation of dielectric loss (tan) with temperature (t C) plots were depicted in figures 1 and 2 for the pure polymers and composites repectively. New dielectric relaxation peaks were observed in the case of VA-VC and PVDF composites below glass transition temperature. In VA-VC composite the observed relaxation was attributed to the segmental motion of the VA and VC segments. In the case of pure VA-VC polymer the relaxation was known to occur below room temperature (-20 C). Owing to coupling of the polymer segments with the polarization charge of PDT particles it could be possible that the relaxation of the segmental motion has been shifted to higher temepratures.



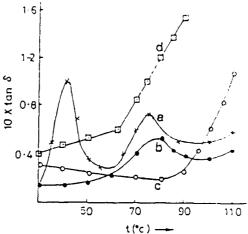


Fig.1. Dielectric relaxations in some polymers used for composite formation (a)VA-VC (b)PVDF (c)ACE (d)NR-PVC

Fig. 2. Dielectric relaxations in the composites (a)VA-VC (b)PVDF (c)ACE (d)NR-PVC

In the case of PVDF, a relaxation around 70 C was known to occur due to the segmental motion in the TGTG configuration. No such relaxation was however, known for the all trans (TTTT) configuration. In fact, the starting PVDF material (fig.lb) didnot show any relaxation peak around this temperature. The observation of new relaxation peak in the composite at about 80 C (fig.2b) was therefore ascribed to the partial conversion of the TTTT to the TGTG configuration. Relaxation due to the segmental motion of NR-PVC and ACE composites were not observed in the experimental range of temperature viz 30 to 150 C. The high temperature 4- relaxation owing to the motion of the main polymer chain near glass transition was mostly unchanged in the composites.

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POSTER SESSION II

MICROWAVE DIELECTRIC PROPERTIES OF Pb(Zr,Ce)O, CERAMICS

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ABSTRACT: We developed Pb(Zr,Ce)O $_3$ ceramics having a high dielectric constant(E $_f$), a high Q and a negative temperature coefficient of the resonant frequency(T $_f$). Combining this with a conventional dielectric ceramic, we made a ceramic which exhibited E $_r$ *170, Q=1200, and T $_f$ *80ppm/ $^{\rm O}$ C at 3GHz.

1. INTRODUCTION

The ceramic required to make a good microwave resonator must have three important dielectric properties.

- (1) A high E_r to miniaturize the size of resonator in proportion to $1/f_r\sqrt{E_r}$. (f_r is the resonant frequency)
- (2) A high Q factor to keep the power loss as low as possible.
- (3) A low $T_{\rm f}$ to stabilize the resonant frequency.

We investigated microwave resonators at 3GHz which need high $\rm E_{r}$ because the frequency of 3GHz is a rather long wavelengh for microwaves. There are some conventional ceramics having high $\rm E_{r}$, high Q and a large positive $\rm T_{f}$ at microwave frequencies. It is conceivable that ceramics having negative $\rm T_{f}$, can be combined with the conventional ceramics to produce a resonator having an extremely small $\rm T_{f}$. The purpose of our study was to develop ceramic compositions having high $\rm E_{r}$, high Q and a large negative $\rm T_{f}$.

2. EXPERIMENTAL

2.1. Sample Preparation

All the starting materials- PbO, 2TO_2 and CeO_2 with a purity of above 99.8%- were weighed to give the compositions in Fig.1. These materials were ball milled for 16 hrs, then dried and calcined at $850\,^{\circ}\text{C}$ for 1 hr. The product was reground in a ball mill, then dried. The powder was pressed into disks and hot pressed at $1250\,^{\circ}\text{C}$ for 4 to 10 hrs under a pressure of 100 to $250\,\text{Kg/cm}^2$. The hot-pressed disks were cut into a form having a resonant frequency of approximately 3GHz.

2.2. Measurements

Dielectric properties at microwave frequencies were measured by the resonant cavity method in the TE_{018} mode. A sample was inserted into a wave guide which acted as a band rejection filter, resulting in a dip curve on the network analyzer display. The unloaded Q was calculated from the resonant curve. The E_{f} was calculated using the value of the f_{f} and the size of the sample. The T_{f} was measured in a temperature range from -20°C to 60°C.

3. RESULTS AND DISCUSSION

Figure 2 shows the relation between $\mathbf{E}_{\mathbf{r}}$, \mathbf{Q} and $\mathbf{T}_{\mathbf{f}}$ as a function of the Pb/2r ratio when the CeO₂ content is constant at 5mol% from (A) to (B) in Fig.1. We found the value of E, and Q was highest when the ratio is slightly over one. Figure 3 shows the change of the dielectric properties against CeO, contents from (C) to (D) in Fig.1. Hot-pressed PbZrO3 without CeO2 is well sintered, but has a Q so low it cannot be measured at 3GHz. The small addition of CeO_2 to $Pb2rO_3$ improves the dielectric properties, especially the Q value. We found an excellent composition of Pb_{1.06}(2r_{0.98}Ce_{0.02})O_{3.06} ((E) in Fig.1) which has a high $\rm E_r(140)$, a high Q(850) and a large negative $T_e(-1080 \mathrm{ppm/}^{\circ}\mathrm{C})$. The microstructure of a Pb(2r,Ce)O₃ is shown in Fig.4 and the relation between the diameter of grains and the CeO₂ content is shown in Fig.5. It should be noted that (E) has the largest grain size and gives the best E_r and Q. We suppose that the addition of CeO_2 to $PbZrO_3$ increases the sinterability of $PbZrO_3$ and improves the dielectric properties. Table 1 shows the combination properties of a stacked ceramic formed of (E) and a conventional ceramic.

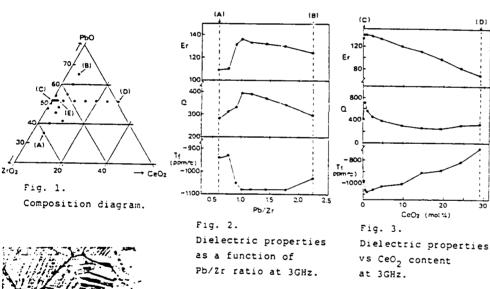


Fig. 4. Microstructure of a Pb(Zr,Ce)O₃

D(u) /	`. <u>.</u>				
s <u>fi</u>	1	- 2	3	4	
		CeOx			

Fig. 5. The relation between grain size and CeO₂ content.

TABLE. 1.
Dielectric properties of combined ceramics at 3GHz.

Comp	(1) PbZrO ₃ -CeO ₂	(2) SrTiO3- NiO - Nb2Os	(1)+(2)
Er	140	230	170
a	85C	2800	1200
Tr (ppm -c)	-1080	1250	80

T-2

HIGH DIELECTRIC CONSTANT CERAMICS FOR MICROWAVE RESONATORS

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ABSTRACT: Dielectric ceramics consisting of BaO-Sm₂O₃-CeO₂-La₂O₃-TiO₂ were investigated for applying microwave dielectric resonators. The material developed has the following properties: dielectric constant (Err: 75.5, unloaded Q(Qu);1870 at 5GHz, and temperature coefficient of resonant frequency, (Tf);0 ppm/*C. X-ray analysis shows that the main compound of the ceramics are Ba(RE)₂Ti₅O₁₄: RE = Sm, Ce, La. The addition of CeO₂ makes this material susceptable to HF+HNO₃ mixed acid.

1. INTRODUCTION

Dielectric ceramics having a high values of Er and Qu, and a small value of T_4 are necessary for ministurizing microwave devices such as dielectric resonators. BaTi $_4O_7$ has high value of Er, however Tf is not 0 ppm/ $^{\circ}C$. We have investigated the effect Sm_2O_3 , CeO_2 and La_2O_3 addition in (BaO) $(TiO_2)_4$ and succeeded in developing new dielectric ceramics.

2. EXPERIMENTAL PROCEDURE

The starting materials were $BaCO_3(G.R.)$, $TiO_2(G.R.)$, $Sm_2O_3(99.9\$)$, $CeO_2(99.9\$)$ and $La_2O_3(99.9\$)$. They were mixed with distilled water in a pot and then dried. The mixed powder was calcined at $1080^{\circ}C$ for 2h in air. After the calcination, the sample was pulverized in a pot and dried. Calcined powder was granulated and pressed into disks and then sintered in an alumina crucible at $1250^{\circ}C$ to $1400^{\circ}C$ for 2h in air.

The microwave dielectric characteristics were measured by Hakki and Coleman's dielectric resonator method $^{\rm 10}$ improved by Robayashi and Tanaka $^{\rm 20}$.

3. RESULTS AND DISCUSSION

Figure 1 shows the diagram of the (BaO)(Sm2O3·CeO2·La2O3)(T1O2)4 system. The hached areas I and ${\rm I\!I}$ were examined in the present study. Figure 2 shows the dependencies of Er. Qu and T₄ on W2 in (BaO) \((Sm2O3) \(\alpha_842 = \war\) (CeO2) \(\alpha_158 \) (La2O3 \(\alpha_2 \) (T10₂)4 in area I. Tf increases with an increase in W2 and becomes 0 ppm/°C at w2=0.1, where Er and Qu are 75.5 and 18°C (5GHz), respectively. Figure 3 shows Er, Qu and T_1 as functions of a particular set of we and wz in (BaO) $\{(Sm_2, Sm_2, Sm_3, Sm$ \mathbb{E}_3)_{1-W1-W2}(CeO₂)_{W1} (La₂O₃)_{W2} (TiO₂)_&. In this case, Tf is almost zero (011 ppm/°C) in the whole experimental range. Er and Qu are constant in the range, Wi=0 \sim 0.175 and $wz=0.154\sim0.09$, $Wi=0\sim0.3$ and $Wz=0.154\sim0.045$, respectively. These findings indicate that if the compositions of the ceramics vary along the line \overline{AB} in Figure 1, they always give Tf=0 ppm/°C. Similar experiments showed that the lines $\overline{\text{DE}}$ and $\overline{\text{FG}}$ in Figure 1 give the compositions corresponding to $\overline{\text{Tf}}$ =10 and +10 ppm/*C, respectively. X-ray analysis shows that main compound of the C point ceramics was Ba (RE) $_2$ Ti $_5$ O $_{14}$: RE = Sm , Ce , La . The chemical etoning property is important for the metallization of the ceramics. Figure 4 shows the SEM photographs of samples as-sintered and etched in a (HF-HNOg) acid solution.

The ceramics containing CeO2 are easily etched in this acid.

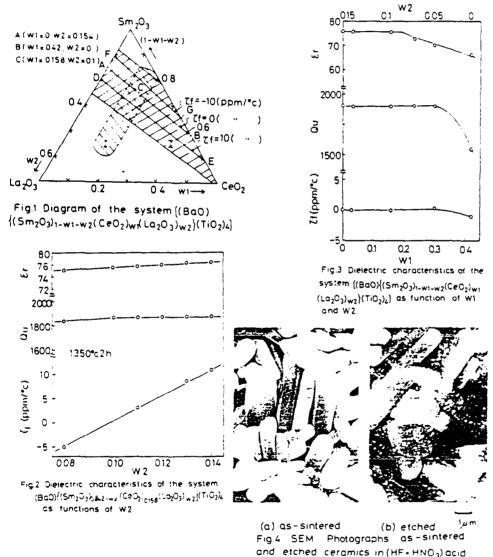
4. CUNCLUSION

The BaO-Sm₂O₃-CeO₂-La₂O₃-TiO₂ ceramics have excellent dielectric characteristics in the microwave region. X-ray analysis shows that the most suitable ceramics for resonators are mainly consisting of Ba (RE)₂ Ti₅O₁₄: RE = Sm. Ce., La. The ceramics are susceptable to HF containing acid. This property makes metalization by chemical plating very easy. These ceramics, therefore, are useful for microwave resonators.

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3. F. Ayusawa, M. Nakayama, H. Sato, M. Kazara and S. Jano, National Conference Pecord Communications, The Institute of Electronics and Communication Enginesis of Japan, 1-64(1964). HIGH-Q DIELECTRIC RESONATOR MATERIAL FOR MILLIMETER-WAVE FREQUENCIES

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ABSTRACT: Microwave characteristics of the system Ba $(Mg_{1/3}Ta_{2/3})O_3$ -BaSnO $_3$ were investigated. Although Ba $(Mg_{1/3}Ta_{2/3})O_3$ had a perovskite pseudocell and hexagonal superstructure, the superstructure was not formed after the addition of BaSnO $_3$ of more than about 10 mols. Sintering of solid solution Ba $(Sn_{0.1}Mg_{0.3}Ta_{0.6})O_3$ was accelerated compared to those of Ba $(Mg,Ta)O_3$ alone, and the microwave Q value was also improved. The resultant dielectric characteristics are as follows: K=24.5, Q=20,000 at 10 GHz, and temperature coefficient of resonant frequency, $\mathcal{T}_5=0$ ppm/°C.

1. INTRODUCTION

Dielectric resonator ceramics have gained an important position as a key element for microwave components. Among many materials developed for dielectric resonators, those with complex perovskite structure have very high Q values $^{1-3}$. Complex perovskite materials of the system Ba(Mg,Ta)O $_3$ -BaSnO $_3$ are investigated here. This system presented a very high Q value and would be useful for applications of millimeter-wave frequency.

2. EXPERIMENTAL

2.1. Materials

Reagent grade BaCO $_3$, MgCO $_3$, Ta $_2$ O $_5$, and SnO $_2$ were mixed by ball-milling for 16 h. They were dried and calcined at 1200 °C for 2 h. The powder was milled again with organic binder, pressed into discs 12 mm in dia. and 5 mm thick and then sintered at 1550 °C for 4 h.

2.2. Measurements

The crystal structure was examined using powder X-ray diffraction, and the microwave dielectric characteristics were measured by Hakki and Coleman's dielectric resonator method.

3. RESULTS

Ba $(\mathrm{Mg}_{1/3}\mathrm{Ta}_{2/3})\,\mathrm{O}_3$ has pseudocubic unit cells with hexagonal superstructures because the two B-site ions are of ordered configuration. Fig. 1 shows the X-ray powder diffraction patterns of this material. The Miller indices parameters in the figures are those of hexagonal superstructure, and the peaks marked by an asterisk are caused by the formation of superstructures.

This material, however, has the problem that it is difficult in sintering to dense ceramics. The addition of ${\tt BaSnO}_3$ accelerated the sintering and improved the Q value. Fig. 2 shows that the optimum Q value is obtained by the addition of about 10 mol% ${\tt BaSnO}_3$. The peaks of superstructure have disappeared in the X-ray diffraction patterns of ${\tt Ba(Sn}_{0.1}{\tt Mg}_{0.3}{\tt Ta}_{0.6}){\tt O}_3$.

Fig. 3 shows the frequency dependence of this Ba(Sn,Mg,Ta)O $_3$ ceramic whose Tf is optimized to 3 ppm/°C.

4. DISCUSSION

We reported that the Q value of Ba(Zn,Ta)O $_3$ was improved by the addition of BaZrO $_3$ whose lattice constant is larger than that of Ba(Zn,Ta)O $_3$. In the system Ba(Mg,Ta)O $_3$ -BaSnO $_3$, BaSnO $_3$ also has the larger lattice constant of 4.12 Å, i.e., pseudocubic unit cells of Ba(Mg,Ta)O $_3$ has the lattice constant of 4.08 Å. The B-site ions in the solid solution are assumed to be more strongly bonded in the oxygen octahedron than in Ba(Mg,Ta)O $_3$ itself. And this strong bonding seems to improve the Q value of solid solution, adding to the effect of accelerated sintering.

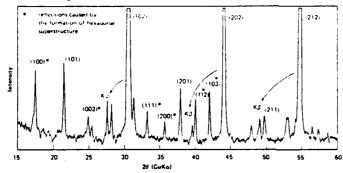


Fig. 1. X-ray powder diffraction patterns of Ba $(Mg_{1/3}^{Ta}a_{2/3})$ 03

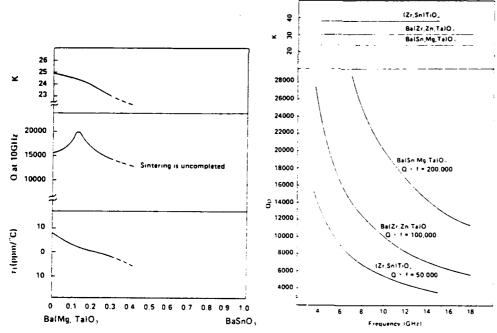


Fig. 2. Dielectric characteristics of Ba $({\rm Mg\,, Ta})\,{\rm O}_3-{\rm BaSnO}_3$ ceramics.

Fig. 3. Frequency vs K and Q for Ba(Sn,Mg,Ta)C₃ ceramic.

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DILLECTRIC PROPERTIES OF BAO TO WO SYSTEM AT MICROWAVE TREQUENCY

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ABSTRACT. Microwave Properties of BaO-TiO-WO, ceramic system were investigated. Addition of a small amount of WO₃ to BaO-XTiO₂ leads to an explicit improvement of Q and Ti (temperature coefficient of resonant frequency). Microwave properties of the compositions with N=4 to 4.5 and Y=0 to 0.04 in the equation of BaO-XTiO₂ (1+X)YWO₃ were observed. With the range of N=4 to 4.3 and N=0.02 to 0.005, higher Q values (BRRO-MRRO at 6GHz) and lower Ti values of nearly zero 1=0.5 to 2.5 ppm² C) with E of 35=38 were obtained. These ceramics had three kinds of crystallines composed of $Ha11_4O_6$, $Ha21_6O_{20}$ and $HaWO_4$. It was found that these improvements seem to be attributed to $HaWO_4$ crystallines with a negative Ti, which is segregated as a secondary phase by WO₃ addition in the dielectries.

1. INTRODUCTION

Ceramics of the TiO₂ rich region of BaO·TiO₂ system such as BaTi₂O₆⁽¹⁾ and Ba₂Ti₂O₅⁽²⁾⁻⁴¹ are well known to be good dielectric resonator materials at microwave frequency. In order to improve the Q values, such methods as chemical treatment spen of calcined materials or addition of small amounts of Mn²⁾ were reported previously. There are, however, few data on the reduction of ti. The optimum of these published data for BaO·TiO₂ dielectrics are understood as following: BaTi₄O₆ (BaO·4TiO₂): $\epsilon = 38$, Q = 9000 at 4GHz, Q = 6000 at 6GHz), $\tau_1 = 15 \sim 20$ ppm²C⁽²⁾⁽⁴⁾ Ba₂Ti₄O₅ (BaO·4.5TiO₂): $\epsilon = 39 \sim 40$, $Q = 8000 \sim 11.000$ at 4GHz, $Q = 5000 \sim 7300$ at 6GHz), $\tau_1 = 2$ ppm²C⁽²⁾⁽⁴⁾

In our case, the segregated $BaWO_4$ crystallines formed by WO_3 addition have an advantage for both improvement of O and τt . This paper is mainly concerned with the relation between the WO_3 amount, the microstructure and the microwave properties.

2. EXPERIMENTAL

2.1. Material and Procedure

The starting materials composed of BaCO₃, TiO₂, WO₃ and MnCO₃ powder with a purity of 99.7 to 99.9 c_c were mixed to be the designated composition mentioned above, in which MnO was fixed to 0.1 mol c_c . The mixed powder was coloined at 1000°C in air for 4Hrs. Ball milled powder was cold pressed into disks and then sintered at a temperature ranging between 1360°C to 1420°C in O₂ for 2Hrs.

2.2. Measurement

The microwave properties of the dielectrics were measured by the resonant eavity method on the TE₀₁₈ mode at 6GHz, XRD, SEM and EPMA analysis were used to examine the microstructure of the dielectrics.

3 RESULT AND DISCUSSION

In order to study microwave properties for our dielectrics, we selected several points of $X(4\sim4.5)$ in the composition written as $BaO(XTiO_2/(1+X)YWO_3)$.

The properties of BaO-4TiO₂ and BaO-4.5TiO₂ with a small amount of WO₃ (Y=0-0.04) were represented typically in Fig. 1. In each case, the addition of WO₃ at Y=0.02 shows a remarkable increase of Q (7100), 57000-80000-90000, which is however saturated with further addition. It is still difficult to explain this favorable Q behavior. (at Y=0.02)

On the other hand, it is well explained from Fig. 1 and the microstructure of these dielectrics (Fig. 2) that the change of ε and τ 1 seems to depend on the segregation of BaWO₄ and BaTiaO₂₀ in BaO-4TiO₂ or of BaWO₄ and TiO₂ in BaO-45TiO₂. The increase of ε and τ 1 is due to segregation of TiO₂. The decrease of ε and τ 1 is due to segregation of BaWO₄. It is thought from the optimum data of τ_1 , +0.5 ppm ³C for BaO-4TiO₂-0 IWO₅ (Y = 0.02) that BaWO₄ must have negative τ 1 with smaller ε 2 than Ba₂TiaO₂₀ and BaTi₄O₆. The segregation of Ba₂TiaO₂₀ is effective for ε 3 increase and τ 3 decrease. Therefore in order to obtain a dielectric resonator with high O and zero τ 3 with relatively high ε 5, coexistence of three kinds of crystallines of BaTi₄O₆, Ba₂Ti₆O₂₀ and BaWO₄ is required. (ε =35 ~38). The reaction equations with WO₃, which was identified by EPMA quantitative analysis for the microstructures, would be interpretated as follows. Table 1 is the summary of our study.

- (1) $B_0O4T_1O \rightarrow WO_1 \rightarrow B_0T_1O \rightarrow B_0T_1O \rightarrow B_0WO_1$ $B_0T_1O \rightarrow B_0T_1O_0 \rightarrow B_0WO_1 \rightarrow WO_1 \rightarrow B_0T_1O_1 \rightarrow B_0WO_2 \rightarrow T_1O_1$
- (2) $B_0O4.5 hO_0 + W.O_0 \rightarrow B_0.1 hO_0 + B_0WO_0 + hO_0$

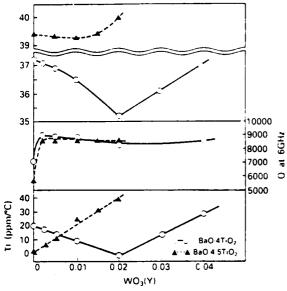
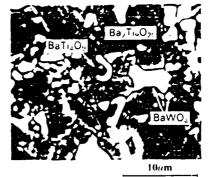


Fig. 1 Dielectric Properties of BaO-4TiO $_2$ (1 ± 4)VWO $_3$ and BaO-4.5TiO $_2$ (1 ± 4.5)VWO $_3$ at 6GHz

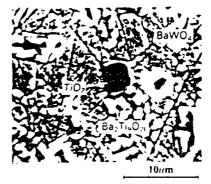
Table 1 Dielectric Properties of BaO(XTiO₂ (1+X)YWO₃

Composition		Properties at 6GHz			05
×	Y	3	Q	Τı	Phase
4.0	-	37	7100	19	BT ₄
4.0	0.02	35	8400	-0.5	BT4, BT4 5, BW
4.2	0.01	37	8800	1.6	BT4, BT4 5, BW
4.3	0.005	38	8300	2.5	BT4, BT4 5, BW
4 5	- :	39	5700	14	BT _{4.5} , BW, T
4.5	0.002	39	8800	4.0	BT _{4.5} , BW, T

BT₄: BaTi₄O₉, BT₄₅: Ba₂Ti₉O₂₀, T. TiO₂, BW: BaWO₄



BaO-4TiO₂-(1+4)0.02WO₃



 $BaO-4.5TiO_2 \cdot (1 + 4.5)0.002WO_3$

Fig. 2 Microstructure of BaO 4TiO₂ 0.1WO₃ and BaO 4.5TiO₂ 0.01WO₃

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D.

FERROELECTRIC AND PYROLLECTRIC PROPERTIES OF SPUTTER-DEPOSITED PZT AND PT FILMS

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ABSTRACT: [111]-oriented PZT(90/10) films have been successfully grown with good epitaxy onto the c plane of sapphire and epitaxial Pt film substrates by the rfmagnetron sputtering method. The crystallographic identifications of these PZT and PT films are made by the X-ray and RHEED measurements. Dielectric, ferroelectric and pyroelectric properties of the films are measured. Pyroelectric coefficients at room temperature have been determined as 4.5 and $3.5 \times 10^{-8} \text{C/cm}^2 \text{K}$ for epitaxial PZT and polycrystalline PT films, respectively. Epitaxial PZT(90/10) films on Pt/sapphire possess desirable properties for potential applications in pyroelectric devices.

1. INTRODUCTION

PbTiO₃(PT) is a tetragonal system with a point group of 4mm and its [001] axis is polar. On the other hand, the polar axis of PZT(90/10) belonging to the rhombohedral structure is parallel to the [111] axis. [100] and [111]-oriented platinum (Pt) films have been successfully grown with good epitaxy onto (100)MgO and (0001)sapphire substrates, respectively. These films are also used as lower electrodes.

In this paper, sputter-deposition of [111]-oriented epitaxial films of rhombohedral PZT(90/10) in the perovskite phase, and their dielectric, ferroelectric and pyroelectric properties are mainly described.

2. EXPERIMENTAL PROCEDURE

An rf-planar magnetron sputtering equipment was used to fabricate PZT(90/10) and PT films. The optimum sputtering conditions for these perovskite type film preparation adopted in the present experiment

were a gas content of ${\rm Ar}(80\%) + {\rm O_2}(20\%)$, a gas pressure of $(0.8-2) \times 10^{-2} {\rm Torr}$, an rf power input of around 150%, and a substrate temperature of around 600°C. The Pt films with a thickness of about 0.3 um were deposited epitaxially onto sapphire and MgO substrates by the same method at a substrate temperature of 450°C and also used as substrates for preparing epitaxial PZT and PT films.

3. RESULTS AND DISCUSSION

The crystalline structures of films deposited at various conditions were investigated. At substrate temperatures lower than 580° C, a metastable pyrochlore structure appeared. PZT of perovskite structure were obtained at substrate temperatures higher than about 580° C. The X-ray diffraction pattern of an epitaxial (111)PZT film sputtered on the (111)Pt/(0001)sapphire at the substrate temperature of 610° C is shown in Fig.1. Figure 2 shows a typical RHEED pattern of the epitaxial film. The epitaxial relations were found to be (111)PZT//(111)Pt//(0001)sapphire and $[1\overline{10}]PZT//[1\overline{10}]Pt//[10\overline{10}]Sapphire$. On the

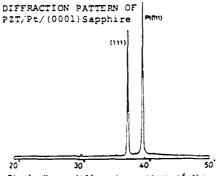


Fig.1 X-ray diffraction pattern of the epitaxial PCT(90/10) thin film on Pt/sapphire.

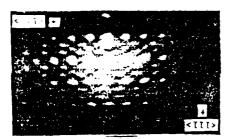


Fig. 2 RHEED pattern of the epitaxial PZT(90/10) thin film on Pt/sapphire.

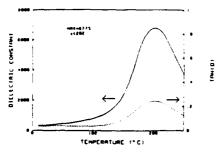


Fig.3 Temperature dependence of the dielectric constant of PZT(90/10) thin film.

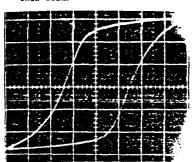


Fig. 4 D-E hysteresis loop of PZT (90/10) film. The thickness is 12µm. Scale units: x axis: 25KV/cm/div., y axis: 15µC/cm²/div.

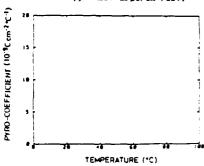


Fig.5 Temperature dependence of the pyroelectric coefficient of as-grown PZT(90/10) film without poling treatment.

other hand, [OOI]-oriented IT films deposited epitaxially on the (100)Piz(00)MgO were not so reproducible in the present experiment. Figure 3 shows the temperature dependence of the dielectric constant measured for an epitaxial PZT. The constant shows an anomaly at the transition point of 202°C and its value at room temperature is 550. The dielectric constant maximum for the PZT film shows a broad temperature dependence and the To of the film is approximately 60°C lower than that of the PZT(90/10) ceramic. It would be considered that the disagreement of To between the film and the ceramic could be attributed to compositional difference of the film and/or to the thermal stress in the film caused by the difference in the thermal expansion coefficient between PZT and sapphire. D-E hysteresis loops were observed on the epitaxial PZT film as shown in Fig.4. The film thickness is 12 um. The coercive field Ec is 35kV/cm. Ec is remarkably larger than that of the PZT ceramic (llkV/cm). This higher Ec observed on the film is due to the small grain size and internal stress. On the other hand, the remanent polarization Pris $35 \mu \text{C/cm}^2$ which is the same value of the PZT ceramic. Pyroelectric currents were observed in as-grown epitaxial [111]-oriented PZT films even without poling treatment and the directions were from upper to lower electrodes. Figure 5 shows the temperature dependence of the pyroelectric coefficient measured on the as-grown epitaxial film. The pyroelectric coefficient at room temperature is 3 x 10^{-9} C/cm²K. In addition, the phase transition from a lower temperature rhombohedral ferroelectric phase $F_{R(LT)}$ to a higher temperature rhombohedral ferroelectric phase FR(HT) was observed at 60°C. When the poling treatment was carried out in a direction coinciding with the direction of pre-existing internal bias, the pyroelectric coefficient increased. The pyroelectric coefficients of the epitaxial FZT and polycrystalline PT films with poling treatment were determined as 4.5 and $3.5 \times 10^{-8} \text{C/cm}^2 \text{K}$ at room temperature, respectively. Accordingly it was concluded that the [111]-oriented epitaxial PZT(90/10) film is one of the most promising materials for pircelectric applications.

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PYROELECTRIC AND ELECTRICAL PROPERTIES OF MODIFIED LEAD TITANATE CERAMICS

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ABSTRACT: Pyroelectric and electrical properties of the modified (Pb, Me)· $[(Co_{1/2}Ti_{1/2}), Ti]O_3$ ceramics (Me=Ba, Ω r or Ca) containing small amounts of MnO and NiO have been investigated. These ceramics are characterized by high apparent density, small dielectric constant (about 200) and facility in poling procedure. Among the ceramics substituted with the alkaline earth metals, the Ca-modified ceramics show markedly excellent pyroelectric and piezoelectric properties. Various kinds of pyrcelectric detectors and ultrasonic transducers have been developed by employing these modified PbTiO₃ ceramics.

1. INTRODUCTION

The modified PbTiO₃ ceramics have been regarded as good pyroelectric and electrical materials, because of their large pyroelectric coefficient, small dielectric constant and high Curie temperature. The present paper reports the pyroelectric and electrical properties of (Pb, Me)[(Co_{1/2}W_{1/2}), Ti]O₃ ceramics (Me=Ba, Ω r or Ca).

2. EXPERIMENTAL

2.1. Materials

Raw materials were calcined at 900°C for 2 hours in air after weighing and mixing. The mixture were formed by die pressing and fired at $1050 - 1200^{\circ}\text{C}$ for several hours. Because of the low firing temperature and small amount of PbO vaporization, the mixture was not fired in PbO atmosphere.

2.2. Measurements

The spontaneous polarization values were measured by the Sawyer - Tower method and relative dielectric constants were measured by ordinary method. Using the system in Fig. 1, we have measured pyroelectric coefficient values.

3. RESULTS

Figure 2 shows pyroelectric coefficient P, relative dielectric constant ϵ and figure of merit F_V for $(Pb_{1-X}Ca_X)[(Co_{1/2}W_{1/2})_{0...96}Ti_{0...04}]O_3$ as a function of Ca concentration. As Ca is introduced into PbTiO₃ ceramic, the pyroelectric coefficient increases to a great extent.

Curie temperatures and coupling factors for the $(Pb_{1-X}Me_X)[(Co_1/v_1W_1/v_1)_0]$, *6. Ti_{0.04}]O₃ system are shown in Fig. 3 and Fig. 4, respectively. From Fig. 4, it is found that these piezoelectric materials have an extremely anisotropic piezoelectric effect.

4. D. SCUSSION

The improvement of pyroelectricity by the Ca introduction into $PbTiO_3$ host lattice may be attributed to the increase of the spontaneous polarization as shown in Fig. 5.

The large piezoelectric anisotropy of these ceramics may be understood when the piezoelectric properties are deduced from the electrostrictive coefficient and the piezoelectric constant d_{31} disappears for a particular ratio of the electrostrictive coefficients and a certain degree of polarization.¹³

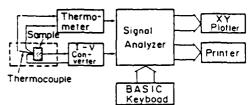


Fig. 1. Schematic diagram for measuring pyroelectric coefficient F.

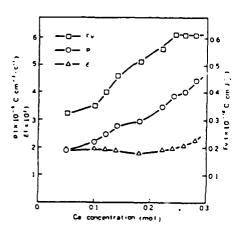


Fig. 2. Pyroelectric coefficient P, relative dielectric constant c, and figure of merit Fv for $(Pb_1-x, Ca_X)[(Co_1-yW_1-x), Ti]0$, as a function of Ca concentration.

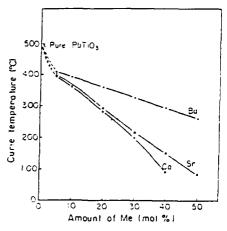


Fig. 3. Curie temperature vs amount of Me for $(Pb_{1-X}Me_X)\{(Co_1 >_2 W_{1-2})_{0.3}eTi_{0.00}(C)\}$ system.

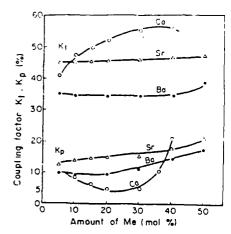


Fig. 4. Coupling factors vs amount of Me for $(Pb_1-xMe_X)[(Co_1/xW_1/x]_{0..14}Ti_{0..14}Ti_{0..14}]0_3$ system.

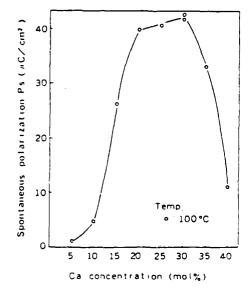


Fig. 5. Relation between spontaneous polarization Ps and Ca concentation of $(Pb_{1-\chi}, Ca_{\chi})[(Co_{1/2}W_{1/2}, Ti]]0$, ceramics.

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Properties of Hot-Pressed Lead Germanate Silicate Ceramics

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Lead germanate (Pb₅Ge₃O₁₁) single crystal has large pyroelectric coefficients and relatively small dielectric constants, heing expected to the use for an infrared detector. However, pyroelectricity and optical-activity in the ceramics have not been so much satisfactory. This is because that the lead germanate has large anisotropy of crystal-structure and that poling is difficult in the ceramics. Therefore many researchers have been studied concerning the polar-axis oriented crystal growth behaviors and substitutional effects of Si and Ba for lead germanate. K.Takahashi et al have succeeded in polar-axis oriented thick-film lead germanate silicate monocrystal by the grass-recrystal-lization method. Also, G.Kirer et al have grown thin-film of lead-germanate by reactive dc-sputtering. 3)

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On the other hand, we obtained grain-oriented ferroelectric ceramics of bismuth-layer type and tungsten-bronze type by hot-pressing method. $^{4-7)}$ This indicates that if the same method is applied to the lead germanate, the similar grain-oriented ceramics can be prepared. In this study, grain-oriented silicate modified lead germanate ceramics were prepared by hot-pressing. The microstructure, and the dielectric and pyroelectric properties of grain-oriented lead germanate silicate ceramics were measured and discussed.

The lead germanate silicate with the composition of $Pb_5Ge_{3-x}Si_xO_{11}$ (hereafter abbreviated to PGSO/x) were prepared, using pure grade PbO, GeO_2 and SiO_2 as starting materials. They are boll-milled and calcined for 5 h at $SOO^{\circ}C$, then melted in the alumina crucible and hold at $SOO^{\circ}C$ for 10 min, and subsequently, quenched to get glassy material. The glassy material were calcined at $SOO^{\circ}C$ for 30 h in air.

The powders were pressed uniaxialy into compact of 15 mm in diameter and 20 mm in height unxtr a pressure of 1000 kg/cm². The green compact was hot-pressed at 600 °C for 5 h under 100 kg/cm² pressure in the oxygen atmosphere. The hot-pressed ceramics were sliced with the normal direction to the slicing plane perpendicular $(P\perp)$, or parallel (P//), to the direction of hot-pressing. For the measurement of the electrical properties, gold was sputtered on the both faces of the plate samples.

The temperature dependence of the relative permittivity for the hot-pressed lead germanate silicate is shown in Fig. 1. In the all composition, permittivities of P// sample are 1.5 to 4 times larger than that of P \perp sample. Especially, the anisotropy of about 4 times in the permittivity at Surie point was found in the PGSO/0.25 composition.

The D-E hysteresis loops for the hot-pressed PGSO/0.25 are shown in Fig. 2. A typical hysteresis loop was observed for P// sample. On the other hand, a linear D-E relationship without any hysteresis was observed for P \perp sample.

The remanent polarization of 900 and pl sample was it and O puter. respectively.

The pyroclectric coefficient as a function of temperature for the hotpressed PCSO/0.25 ceramics is shown in Fig. 3. The peak of the pyroelectric coefficient at about 70°C was about 15X10⁻²µC/cm²°C in P// sample. On the other hand. pyroelectric coefficient of F 1 sample was about 0 between 15 and 150°C. The pyroelectric coefficient in P// at room temperature was about $2.5 \times 10^{-2} \mu \text{C/cm}^2$ °C, was as same as that of LiTaO3 single crystal and 3 to 4 times as large as that of LiNbO3 single crystal.

These results indicated that the each polar-axis (c-axis) of lead germanate silicate crystals were oriented parallel to the hot-pressing direction. In the crystal growth of lead germanate single cryscal, the easy crystal-growth direction is the c-plane, hexagonal place-shaped grains are formed in the early stage of the crystal growth or glassrecrystallization. Therefore, during hor-pressing, the place-shaped crystallites are created in the early stage of the firing process and they are aligned perpendicular to the hotpressing direction. In the hotpressed lead germanate silicate, the c-axis anx poler-axis of ceramics are arranged parallel to the hot-pressing direction.

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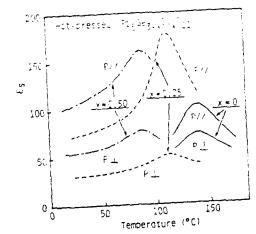
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Fig. 1. Temperature dependence of dielectric constant of hot-pressed lead germanate silicate ceramics.

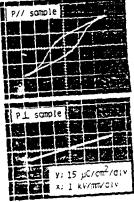


Fig. 7. D-E hysteresis loops for hot-pressed Pb_5^{Ge} 2.75 51 2.75 01 1 ceramics.

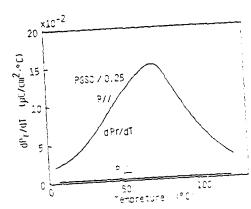


Fig. 3. Pyroelectric coefficient as a function of temperature for hotpressed Pb3Geg -3510 250. ceramics

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COMPARISON: THERMAL AND MECHANICAL PROPERTIES OF BARROW TITANATE VERSUS LEAD PERCYSHITE DIELECTRICS

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ABSTRACT: Thermal and mechanical properties of solid ceramic and multilaver ceramic chips were measured and the properties of barium titanate-based dielectrics were compared to a lead perovskite dielectric material. Fracture toughness and bend strength values indicate that the lead perovskite dielectrics are relatively weak. Thermal shock experiments show that thermal stresses cause unstable crack propagation in barium titanate dielectrics whereas a stable crack propagation occurs in the lead perovskite dielectrics.

1. INTRODUCTION

Recent increased use of surface mount components has placed a major emphasis on the mechanical strength and the thermal shock resistance of ceramic chips. In this study, fracture toughness and modulus of rupture values measured on barium titanate-based commercial dielectrics were compared with a lead perovskite dielectric. Using the measured physical and mechanical properties of these materials, the theoretical thermal shock resistance parameters for fracture initiation, R and R¹, were calculated and compared with the experimental thermal shock results.

2. EXPERIMENTAL

Fracture toughness was measured by an indentation strength method in which the samples were 2! precracked with a micro indentor and then fractured by a four point bend testing method . Modulus of rupture was measured by a simple three point bending technicque.

Thermal snock resistance was measured by neating the chips to various elevated temperatures, quenching into room-temperature water and then measuring the three point bend strength of the quenched samples. All tests were performed on a 5819 size (14.7 x 4.8 x 1.5 mm) solid and multilayer this.

3. PESULTS AND DISCUSSION

The experimental data show that the lead percyskite dielectric is soften and mechanically meaker than the carrum totanate-based dielectric. Theoretically calculated thermal shock new contained parameters also indicate that these dielectrics are inferior to parium ditanate-based dielectrics. However, experimental thermal chock results indicate that the lead percyskite dielectric dater of remained differently report the contained dielectrics. Balling

(2).

dielectrics show a sudden drop in strength at a critical temperature differential of approximately 75 to 100°C, whereas, the lead perovskites show a gradual decrease in strength.

Microscopic observations of the thermal shocked chips show many surface chacks in BaTiD3 dielectrics and few or no chacks in the lead perovskite dielectrics. The experimental results suggest that in BaTiD3 dielectrics fracture occurs by unstable chack propagation, due to thermal stresses, and in the lead perovskite dielectric, stable chack propagation occurs.

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ABOTRACT: Mechanical failure of henat, and a control of the aller of the analysis of the analy

Gix capaciton behavior were used in this study? The Havenia of a considerationally to uptual Lapacition with the construction of the constructions of maps electrode interactions. Indeption of the foreign electrode were used to measure fig. as well as to assess the passive effects of other accountricitie fracture penation of these materials and to connectate discertifications of these materials are determined by conducting dynamic fatigue tests in water or one output terms of the connectations.

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Susceptibility to moisture enhanced chaptering as all the formal of papaciton composition. Chapter growth exponents, No manged formal to the decided dynamic fatigue curves for the two (TR compositions suggested the expose materials.

TABLE 1. Compositions and Properties of Japanison Senseties

Designation	Major Constituent	378.7 s.28 15	<u> </u>	<u> *:</u>
::20	Rare earth oxige	· - 3	* , •	
X?8-1	BaTiC ₃ (Bi)	g '	* . *	
X_B-5	BaTiOg	<u>.</u> '		
15U	BaTiO ₃	:-*	-	
250 "high"	BaTiO ₃	3-7	• , •	
ag:ng	•			
250 "low"	SaTio ₃	; = ?	*	
aging	-			

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COMPOSITIONAL INFLUENCES UN PLZT SWITCHING PROPERTIES

8 OEPNE, F WALLENHORST and J. KYONKA Honeywell Inc., Minneapolis, MN

ABSTRACT, malf-wave voltages, polarization and capacitance were measured for a series of PUZT samples with varying La contents and Zr/Ti ratios. These parameters, particularly malf-wave voltage, are unitical in the design of active PUZT optical components. Lower values of half-wave voltage are highly desirable. This work establishes that as the La content exceeds 9.4 atom t and as the Zr/Ti ratio exceeds 65/35, undesirable increases in half-wave voltage will result.

" INTRODUCTION

PLIT materials have been extensively studied since the high transparency of the lanthanum modified lead zinchnate-lead titanate family was discovered by Haertling in 1969^{1}). These materials have been used or marrly in optical shutter applications²). Most of the study efforts have concerned compositions prepared to the formula

$$^{\text{Fb}}_{1-x}(Z^{\text{F}} 65^{\text{T}}, 35) 1-\frac{x}{4} ^{0}3.$$

with x ranging from 090 (9.0 atom % La) to .100 (10.0 atom % La). When the compositions are used in ontical snutter annihilations, low switching times and low half-wave voltages are both desirable. This investigation was carried out to determine if both reduced switching time and lower half-wave voltages could be found in compositions with Zr/Ti rat os above 65.35 and La contents above 9.5 atom %.

. EXPERIMENTAL PROCEDURE

In the na toware vs tage tests, a white light source was used with a convencing lens, infeshed lens, and aperture to provide the testing light beam. A linear colarizer along with green and IP for tensial swed on vipolarized light of the desired wave length to enter the null sample. The Pull sample was followed by a second objanizer at v000 to the first, and a detector to measure this in thed light. The voltage to the Pull sample was namped upward with votem transmission was caken as na fiveselve, tage.

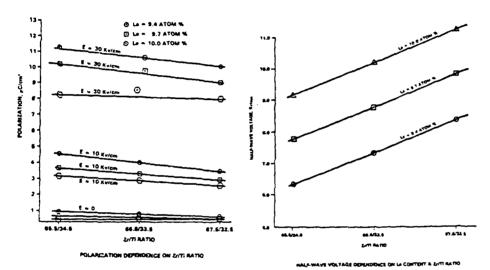
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Results and sate publiant all configner numbering unitage requirements with increasing La

content. In addition, it is snown that increasing Zr/Ti ratios also result in nigher half-wave voltage levels.

Switching times measured in the test described above ranged from 45 to 75 microseconds over the nine compositions tested. Data scatter was such that no trends were detectable through the composition range tested. Data scatter was thought to be due to mechanical oscillations of the PLZT wafer following discharge.

Polarization is shown to be inversely related both to the Zr/Ti ratio and to the La content. Variations of the La content resulted in substantially larger changes in polarization than variations in the Zr/Ti ratio. Wafer capacitance, and therefore the material dielectric constant, is shown to be inversely related to both the La content and to the Zr/Ti ratio.



4. DISCUSSION

This work shows that, as the Zr/Ti ratio is raised above the 65/35 level, the half-wave voltage increases for 9.4 atom percent and higher La contents. Switching time measurement scatter was such that differences between samples were not detectable. The wafer capacitance and therefore dielectric constant is inversely related to both the La content and the Zr/Ti ratio. Polarization is inversely related to both La content and Zr/Ti ratio. The results of this work indicate that Zr/Ti ratios of less than 65/35 along with La contents of less than 9.4 atom percent should be explored. It appears that lower half-wave voltages can be achieved with probable minor impact on switching time but at some cost in higher dielectric constant and polarization values.

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FLECTRUMECHANICAL FAILURE PREDICTIONS

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ABSTRACT: Dielectric and piezoelectric ceramics such as barnum titanate and P2T are known to be subject to environmentally enhanced crack growth. That is, if a static mechanical stress, Oa, is imposed on such ceramics in the presence of water vapor, small surface flaws may extend slowly with time until they reach a size at which catastrophic fracture takes place. It has been demonstrated previously that the time to failure, t_f, under such conditions can be calculated from fracture mechanics principles and is given by the expression:

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$$t_f = B S(n-2) \sigma_a - n$$
 (1)

where B is a constant made up of a number of flaw and crack growth parameters, S_i is the initial strength of the material, and n is a constant which is a measure of the crack growth susceptibility of the material. Such an expression has been shown to accurately predict the lifetime of components under static, far field loads.

Increasingly, however, dielectric and piezoelectric ceramics are being operated under conditions, i.e., resonant cyclic fields, where more complex stresses can arise. The purpose of this paper will be to demonstrate how these more complex stress states affect the sensitivity of such ceramics to delayed failure and to begin to formulate expressions which will allow a designer to use these materials safely.

The devices being considered and types of electrical fields imposed on them are shown in Table 1. The key factors which are discussed in this paper are: $\frac{1}{2} \left(\frac{1}{2} + \frac{1}{2} +$

- l. Effects of electrostrictive stresses local to a crack tip generated by the application of a d.c. bias field.
- Cyclic stressing effects due to application of an a.c. field at a resonant frequency.

It will be shown that the presence of these factors can lead to complex expressions for failure time which may not be analytically determinable. Other complexities such as the presence of internal stresses in piezoelectric ceramics and mechanisms of crack growth under compressive loads will also be discussed.

Table 1
Electromechanical Conditions

<u>Device</u>	Electrical Field	Strain Condition	Stress
Capacitors Microdisplacive Devices	Static	Static	Stresses at Flaws increased by Electric Field Concentrations
Piezuelectric Transducers	Cyclic	űyellic	Uniform at cross section
Electrostrictive Transducers a) biased b) non-biased	Static + Cyclic Gyclic	Cyclic + Static Cyclic	uniform at cross section

The relation of anisotropy between crack length and fracture toughness in poled PLZT and modified PbTiO $_{\rm 3}$ ceramics

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Japan

ABSTRACT: A micro-indentation technique was applied to the poled (Pb,La)($Z_{\rm F}$,Ti) O_3 and (Pb,Ca)TiO $_3$ ceramics. Internal stress induced by the DC application of 3KV/mm were measured as the 3.3 MN/m 2 and 65.6 MN/m 2 in the direction parallel and perpendicular to the poling field in the (Pb,Ca)TiO $_3$ ceramics. These anisotropies of internal stress could be also confirmed in the three point bending test. The anisotropy of crack lengths was explained by this internal stress.

1. INTRODUCTION

In general, ferroelectric ceramics were used after DC poling treatment. The electrical properties of the poled ferroelectric ceramics have been widely investigated for the practical use. Mechanical properties in the poled ferroelectric ceramics are important for an improvement of reliability in electronic components. In this paper, the internal stress was measured by using the microindentation (MI) technique. The relation of anisotropy between crack length and fracture toughness was discussed.

2. EXPERIMENTAL PROCEDURE

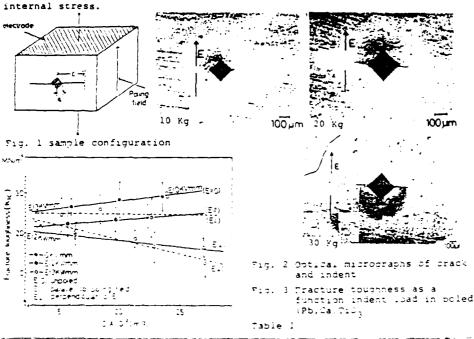
The chemical compositions of the sample for this experiment were $(Pb_{0..76} Ca_{0..24})\{(Co_{1/2}W_{1/2})_{0..04}^{Ti} Ti_{0..96}]0_3$, $(Pb,Ca)Ti0_3$ and $(P_{0..98}La_{0..02})(Z_{T0..5}^{Ti} Ti_{0..5}^{Ti})0_5$, PIZT 2/50/50. The sintered body was prepared by normal sintering for $(Pb,Ca)Ti0_3$ and by hot-pressing for PLZT 2/50/50. The sample dimensions for MI measurement were 7 mm in width, 30 mm in length and 10 mm in thickness, respectively and silver electrodes were attached to the majour surfaces. The side surfaces perpendicular to the electrode were finish ground with 1 μ m gritz alumina and annealed at 800°C for 5 min in order to remove the residual strain induced by the mechanical polishing. The samples were poled in silicon oil at 110°C by applying DC fields of 0 to 3 KV/mm for 10 min. The micro-Vicker's nardness tester was applied as shown in Fig. 1.

3. RESULTS AND DISCUSSIONS

Figure 2 depicted the micrographs of cracks induced by the indent load of 10, 20, and 30 Kg in the poled (Pb,Ca)TiO $_3$ ceramics. The anisotropies of crack length caused by the indent load of 30 Kg was 1.4 times in the direction parallel and perpendicular to the poling field direction. From the length of these cracks, K_{1c} values were calculated from the following formula, $K_{1c} = 0.020 \Sigma^{0.5} p^{0.5} a^{-0.5} (\overline{c},\overline{a})^{-1.5}$

where E is Young's modulus, P in the indent load, a and Y are indent length and crack length, respectively. If the sample has a internal stress, the fracture toughness represents the effective value as shown in the following equation.

where K_{10}^{0} is an intrinsic fracture toughness and \Im is an internal stress. The equation can be applied when the sample has the uniform distribution of stress. Figure 3 shows the fracture toughness as a function of indent loads. The internal stress parallel, $\mathcal{J}_{1}^{\prime}(E\,y)$ and perpendicular, $\mathcal{J}_{1}^{\prime}(E\,L)$ to the poliny field direction were the compressive stress of 11.5 MN/m and external stress of 26.6 MN/m 2 , respectively. As shown in micrographs in Fig.2 and K $_{
m ic}$ value measured by the indent load of 10 Kg in Fig.3, the crack lengths parallel and perpendicular to the poling field direction are almost same and as a result the ${
m K_{1c}(E\,\mu)}$ and ${
m K_{1c}(E\,1)}$ were almost same. Table 1 shows the crack lengths, ${
m c}$ E/ : and $c(E \perp)$ and fracture toughness, $K_{1c}(E \neq)$ and $K_{1c}(E \perp)$ and the ratio of crack length, $\sigma(E,y)/c(F,L)$. The abusotrone of cract lengths became larger at the heavy indent load. If the sample has no internal stress, the die value became to a constant value at the various indent load and the internal stress was zero. Table 1 also represents the crack length parallel and merpendicular to the holing field, $c(2\pi)$ and $c(E\perp)$ and the ratio of $c(E\pi)$ and $c(E\perp)$ calculated from the experimental conditions that the internal stress is zero and $K_{1c}(E,H)=2.33$ M4/m^{1.5} and $K_{1c}(\Sigma\pm)=1.94$ M4/m^{1.5} at the indent load of 20 and 30 Kg. As shown at the right side in Paple 1, the anisotropy of crack lengths parallel and perpendicular to the poline field was reduced. Derefore, the internal stress was induced by the rearrengement of domains by the poling field application and it could be concluded that the anisotropy of cracks was induced from the internal



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MECHANICAL AND DIELECTRIC FAILURE OF Batio, CERAMICS

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ABSTRACT; The present paper reports the alternative method to predict the mechanical failure probability of ferroelectric BaTiO₃ thick films, utilizing the analogy between mechanical and dielectric strength distributions without spending a lot of test pieces. The effects of microstructure and measurement method on the strength distributions are also discussed.

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1. INTRODUCTION

It is still difficult to predict the probability of mechanical failure of ceramic materials. Usual mechanical strength test requires a lot of test pieces subjected to failure, which should be inconvenient from the technological point of view.

Nochanical failure is recognized to be microstructure-sensitive. Especially larger grains and pores are regarded to play an important role as fracture origins. On the other hand, dielectric strength is also proved to be dependent upon microstructural parameters as grain size, porosity, etc., which would lead to the scattering in dielectric strength distribution. Hence, the analogy between dielectric and mechanical strength distributions can be excepted, if the fracture origins in both failures are similar. In the present work, this concept was examined for BaTiO3 thick films as representative ferroelectric geramics.

2. EXPERIMENTAL

The specimens subjected to the test were fabricated by the modified doctor blade method.²⁾ The final thickness of the film was in the range of 180 to 220±m. Mechanical strengths were measured in three point flexture (12mm span). For dielectric breakdown tests, Ag pastes were attached on both sides of the film as the electrodes. The do voltage was applied to a specimen placed in silicon bil and increased at the rate of 50V/sec. Breakdown voltage was determined by measuring the abrupt increase in current. Both the dielectric and mechanical strengths were estimated by the Aeibuil statistics.

3. PESULTS

Weipull clots of the sets of data of mechanical and dielectric strength optained for the specimen sintered at 1300c0 are shown in Fig. as a Typical example. Thise for the over specimens sintered at 1300cd and 1400 to have shown similar distributions on those shown in Fig. .

It is seen in the figure that the distribution-shapes of both strengths are very close to each other, which indicates a similar role of microstructure in both failure, though the decisive factor for fracture is

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20.

On the other hand, Weibull plots for the specimens sintered at 1450 $^{\circ}\mathrm{C}$ revealed different distribution shapes between mechanical and dielectric strength.

4. DISCUSSION

The present results would firmly suggest that the fracture origins $-\mathrm{i} n$ both failures are similar in a small-grained specimen but not in a largergrained specimen. Fairly good correlation in Weibull distributions between mechanical and dielectric strengths can be utilized to predict the mechanical failure probability of a material without spending a lot of test pieces.

Similar experiments were carried out above the Curie temperature to examine if the analogy between mechanical and dielectric failure still Thicker specimens were also subjected to the similar tests. Details will be presented on the poster.

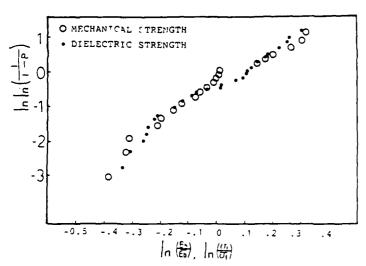


Fig. 1. The WEIBULL PLOTS of the data of dielectric and mechanical strength for the specimen of ${\tt BaTiO_3}$ sintered at 1300 $^{\circ}{\tt C}$

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Toughening of ceramics by crack tip/stacking faults interactions K. NIIHARA
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ABSTRACT: Effects of stacking faults on fracture toughness have been investigated for highly pure and dense 8-SiC ceramics prepared by CVD method. TEM observations revealed that there exist no glassy layers or secondary phases at any grain boundaries. As expected from this facts, the crack deflection by the grain boundaries was not observed for almost all cases. However, the strong crack tip deflection and/or microcrack formation associated with stacking faults were revealed by TEM observation, which suggests the fracture toughness of SiC may be improved by incorporating the stacking faults into the grains. In fact, the toughness increased from 3.2 to 6.8 MN/m^{3/2} with increase in the stacking fault density.

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1. INTRODUCTION

It is well-known that the fracture toughness of $\mathrm{Si}_3\mathrm{N}_4$ and SiC can be improved by controlling the grain morphology, that is, by growing the elongated $\mathrm{Si}_3\mathrm{N}_4$ and SiC grains. However, this toughening mechanism operates only for the $\mathrm{Si}_3\mathrm{N}_4$ and SiC ceramics with the glassy phases at grain boundaries. On the other hand, $\mathrm{Si}_3\mathrm{N}_4$ and SiC ceramics with the glassy phases at grain boundaries show the rapid strength degradation at high temperatures above approximately $1000^\circ\mathrm{C}$. Thus, it seems to be very difficult to achieve both good mechanical properties at high temperatures and high toughness at room temperature at the same time. The aim of this work is to develop new toughening mechanism without help of grain boundary for SiC ceramics. This new toughening mechanism is related with the nonostructure control within SiC grain, i.e. the control of stacking fault density inside SiC grains.

2. EXPERIMENTAL PROCEDURES

The plates (1 to 3 mm thick) of SiC were prepared by chemical vapor deposition (CVD) from a mixture of $C_3\mathrm{H_8}$ and $\mathrm{H_2}\text{-carried SiCl_4}$. The preparation conditions are as follows: deposition temperature ($\mathrm{T_{dep}}$); 1500°C, total gas pressure; 30 to 760 Torr, gas flow rates of $\mathrm{SiCl_4}$, $\mathrm{C_3H_8}$ and $\mathrm{H_2}$; 170, 10 to 55, 700 cm3/min, respectively. The density of stacking faults were controlled by changing the total gass pressure in the furnace and the gas flow rate of $\mathrm{C_3H_8}$, i.e. the deposition rate. Fracture strength was evaluated by three point bending (span; 10 mm, cross head speed;0.5 mm/min). Fracture toughness was estimated by indentation microfracture, double cantilever beam and/or compact tension techniques. Microcracks for TEM observations were introduced into thin discs of CVD-SiC by using Vickers diamond pyramid at room temperature, 800°, 1000° and 1300°C i.. vacuum. The observations around cracks formed by indentation were performed using a JEM 200CX.

3. RESULTS AND DISCUSSIONS

The CVD-SiC prepared are confirmed to be 3 phase by A-ray diffraction, Ma-ever, many stacking faults were observed in the almost all grains, as shown in Fig. 1. High resolutional electron microscopy of these materials revealed that there exist no glassy layers or secondary phases at any grain boundaries and multiple-grain junctions. Thus, strength degradation was not observed up to 1500°C; the strength of SiC

increased with increasing temperature above about 800°C. Is liveral temperature dependence of tracture strength of CVD-SiC is indicated in Fig. 2.

The clear crack tip/stacking fault interactions were observed to TFM as shown in Fig. 1. Thus observations suggest that the fracture toughness of oil may be improved by incorporating the stacking faults into the grain. Therefore, the CVD-SiC with various density of stacking faults were prepared by controlling the total gas pressure and C_3H_8 flow rate and their fracture toughness were estimated by IM, CT and DCB techniques. The results are shown in Fig. 4. The fracture toughness was found to increase remarkedly with increasing stacking fault density inside grains. This new toughening mechanism is considered to make possible the development of SiC ceramics with good strength at high temperatures and high toughness at room temperature.

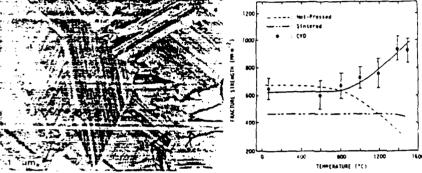


Fig. 1 Transmission electron micrograph of CVD-SiC.

Fig. 2 High-temperature fracture strength for CVD-SiC.

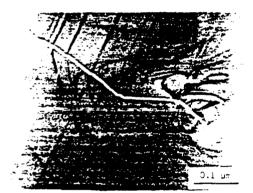


Fig. 3 Crack tip/stacking fault interaction observed for CVD-SiC.

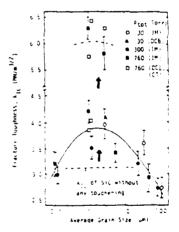


Fig. 4 Fracture toughness for CVD-SiC with various density of stacking fault.

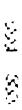


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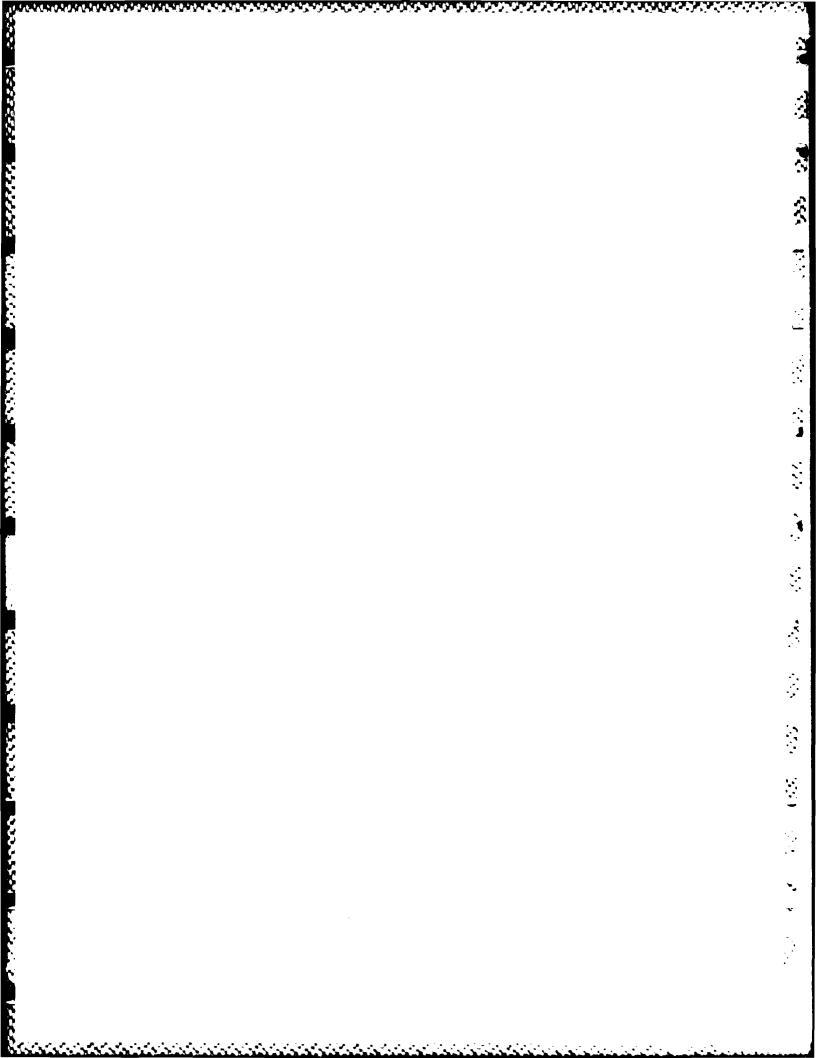












GROWTH AND APPLICATIONS OF TUNGSTEN BRINZE FAMILY CRYSTALS

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ABSTRACT: Ferroelectric tungster tranze T. B. undoped and doped crystals, specifically $\text{Sr}_{0.6}\text{BA}_{0.4}\text{Nt}_{0.6}\text{B}_{0.6}\text{SBN:60}$, and $\text{Ba}_{1+\chi}\text{Sr}_{\chi}\text{K}_{1-\chi}\text{Na}_{\chi}\text{Nb}_{5}\text{O}_{15}$ BSKNN, have been grown using the Grochralski technique. The optical figures-of-merit of these crystals are excellent to test photorefractive and fillimeter wave desire concepts.

1. INTRODUCTION

The present study reports the state-of-art of tungsten bronze family crystals for millimeter wave and photorefractive device studies in terms of their ferroelectric and optical properties.

2. EXPERIMENTAL

Both $Sr_{1-x}Bu_xNb_2O_6$ (SBN) and $Ba_{2-x}Sr_xK_{1-y}Na_yNb_5O_{15}$ (BSKNN) crystals were grown using the Czochralski Technique under different conditions. A variety of measurement techniques were used to evaluate these crystals for millimeter wave and photorefractive applications.

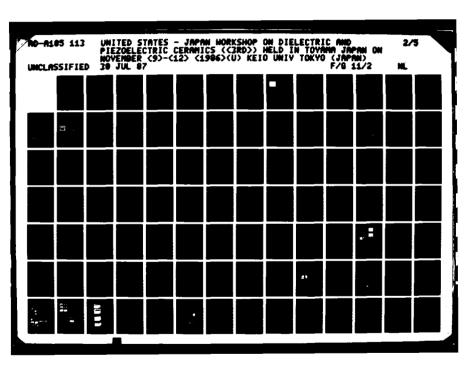
3. RESULTS AND 4. DISCUSSION

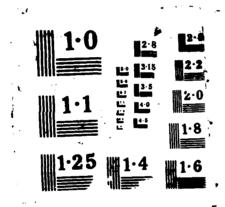
Both SBN:60 and BSKNN compositions are multicomponent systems, and there are several crystallographic sites available for large cations in tungsten bronze structure. Because of these factors, the following problems are encountered in crystal growth:

- Exchange among crystallographic sites, specifically of the 15and 12-fold coordinated ions, and this causes severe striation
- * Reduction of ${\rm Nb}^{5+}$ to ${\rm Nb}^{4+}$ at growth temperature, causing severe problems with quality and composition.

In spite of these problems, Neurgaonkar et al¹⁾ have grown undoped and Ce-doped SBN:60 and BSKNN crystals in optical quality as large as -.5 to 2.6 cm in diameter. Bronze crystals grown along the c-axis are

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usually faceted, which is quite exceptional for Czochralski grown crystals.

Ce-doped SBN:60 crystals, having electro-optic coefficient r_{33} = 420 x 10^{-12} m/V, are found to be excellent hosts for device studies. The photorefractive speed for this crystal can be controlled to 1 ms, depending upon laser power, while undoped SBN:60 crystals exhibit speeds of 1000 ms. This improvement in speed and other enhanced properties such as photorefractive coupling are making this crystal attractive for device applications.

Trends in the measured millimeter wave properties of SBN:60 and BSKNN crystals have been shown to conform to simple models for the loss process and the nonlinear susceptibility 2-3). Measurements have been made over a wide temperature range, down to 20 K, and for frequencies from 35 GHz to 125 GHz. Based on these results, crystal composition and operating temperature can now be selected to maximize particular nonlinear effects for device applications.

ACKNOWLEDGEMENT

This work was supported under the ONR and DARPA contracts.

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PHOTOFERROELECTRIC EFFECTS IN PLZT CERAMICS

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ABSTRACT: Several non-memory PLZT compositions were evaluated for their resistance to the combined effects of high electric field, high temperature and intense light exposure. All materials exhibited behavior which limit their performance under these conditions; however, the photoexcited space charge effects could be eliminated by means of ac rather than do operation.

1. INTRODUCTION

Since the early 1970's when the transparent, slim-loop ferroelectric PLZT materials were first utilized in shutter devices, it was noted that these materials were limited in their performance by residual memory phenomena manifested in a time-dependent deterioration of the OFF condition. Subsequent research investigations (1,2) have contributed greatly to an understanding of these phenomena which are generally classified as (1) residual memory effects resulting from a field-induced ferroelectric state and (2) space charge effects produced by the photoexcitation of charge carriers and their movement under the influence of an electric field. The present study reports on some observed effects in category (2) as they relate to SFE (penferroelectric) materials in transverse-mode, shutter devices.

2. EXPERIMENTAL

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Hot pressed, polished and electroded samples of PLZT compositions 9/65/35, 9.5/65/35, 8/70/30 and 15/40/60 were selected for study. The vacuum deposited, Cr-Au, single-sided, surface electrodes consisted of an interdigital array of electrode widths and gaps ranging from 0.05 mm to 0.25 mm. Electrical and electrooptic measurements were made on the samples as a function of electric field, temperature, time and light exposure. A high intensity mercury arc lamp was used as the light source in conjunction with various filters ranging from 370 nm to several microns.

3. RESULTS

It was found that (1) the PLZT materials evaluated in this study were highly susceptible to the combined effects of high intensity light exposure and high electric fields, (2) the effects are more pronounced at temperatures near or above $T_{\rm C}$ (maximum in dielectric constant, 65°C for 9/65/35) and (3) the effects are time dependent and will always anneal out at a rate which is dependent on temperature and light exposure. A typical set of curves are shown in Figure 1. As noted, the virgin material is symmetric about the zero £ axis, whereas the materials subjected to either a positive or negative bias while illuminated (the usual situation in a shutter device) display varying degrees of light intensity assymmetry. The relaxation time for this effect at 100° C for PLZT 9/65/35 was found to be approximately 5 seconds; consequently, an activated shutter would be totally compensated (turned OFF) by the photoexcited space charge field in this time frame. Likewise, the material could be refreshed in an equal amount of time. This suggests that if the electric field were alternated (+ to -) at a rate faster than the relaxation time, then this effect would be minimal. This, in fact, does occur and driving the shutter at 30 Hz ac was found to be

sufficient to eliminate, at all temperatures, the undesirable space charge effects.

Photoconductive effects in these materials were also studied by monitoring the voltage across a 22 M Ω resistor connected in series with the shutter and the power supply. When a bias voltage was applied to the shutter without illumination, little or no steady state voltage was developed across the resistor; however, when the light source was turned on, several volts (depending on temperature) would develop across the resistor as a result of the conduction of photoexcited space charge across the gaps of the interdigital electrodes. The voltage trace shown in Figure 2 was thus generated by mechanically shuttering the light source at the various rates indicated. This effect was found to be the largest at the short wavelengths. It was also significant across the visible spectrum but not in the IR.

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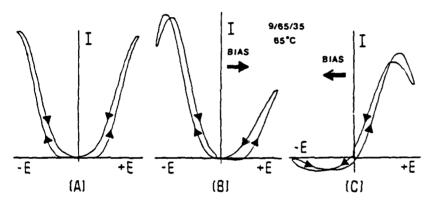


Figure 1. Variation of light intensity as a function of electric field for (A) a virgin PLZT 9/65/35 at 65° C, (B) same sample after 15 minutes light exposure with a + bias of 40 KV/cm and (C) same sample after 30 minutes light and a - bias of 40 KV/cm.

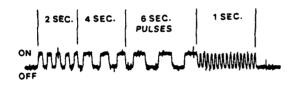


Figure 2. Photoconductivity effects in a PLZT 8/70/30 material as the light is shuttered on and off.

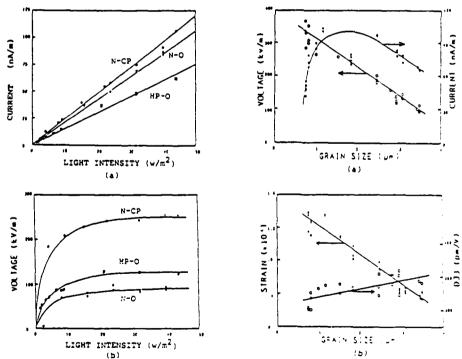
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PHOTODRIVEN RELAY USING PLZT CERAMICS

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Photostriction explainable by the superposition of the bulk photovoltaic effect and piezoelectricity has been investigated in the solid solution ceramics (Pb,La)(Zr,Ti)O $_3$ (3/52/48). Photostriction is strongly dependent on the sample preparation history,i.e. on grain size and remanent polarization.

Three samples were prepared; a) atmosphere sintered of oxide chemicals, b) hot-pressed of oxide chemicals, c) atmosphere sintered of coprecipitated PL2T powder. The last ceramic sample was found to reveal the largest photovoltage and photostriction (Fig. 1). As shown in Fig. 2, the photovoltage and photostriction become larger with decreasing grain size, though the piezoelectric coefficient d_{33} becomes slightly smaller. The highest photovoltage, 2.5-3.0 KV/cm, and the maximum photostriction, 1.0-1.3x10⁻⁴, were obtained at the moment in the ceramic sample prepared by coprecipitation with about 1um grains under $4mW/cm^2$ illumination. Both the photovoltage



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Fig.1 Photovoltaic effect in three samples N=O, Fig.2 Grain size dependence of photostriction HP=O and N=CP

and piezoelectric coefficient d_{33} have a linear relation with the remanent polarization, so that the photostriction is proportional to the square of the remanent polarization (Fig. 3).

Using PL2T(3/52/48) ceramics, we have fabricated a photodriven relay as a trial photostrictive actuator. This relay consists of an optomechanical bimorph-type actuator and a snap action switch, as illustrated in Fig. 4. In order to obtain quick response, the "dual beam method" was applied. Tip deflection over 100 um was observed in the bimorph with 20 mm length (Fig. 5). Though the delay time to the illumination is several seconds, we have observed primitive relay function controlled by optical irradiation. Furthermore, analysis of the relay response is proposed, giving the requirements for photostrictive material characteristics and the optimum shape of the bimorph.

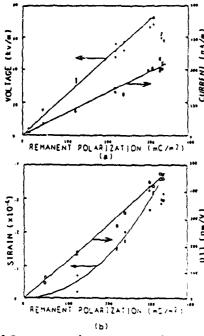
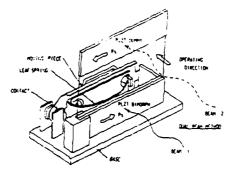


Fig. 3 Remanent polarization dependence of photostriction



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Fig.4 Structure of photodriven relay

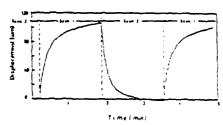


Fig.5 Tipmend deflection of bimorph to the light illumination

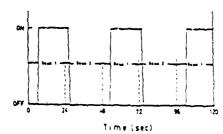


Fig.6 ON/OFF response of newly developed relay

\ \ \ \ PLZT THIN FILM ON MgAl 304/Si SUBSTFATES

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ABSTRACT: PLZT films were sputter-deposited onto (001)MgAl $_2$ O $_4$ /(001)Si substrates using PLZT(x/65/35) powder targets with varied La contents. X-ray and electron diffraction analysis confirmed that PLZT films grew epitaxially along the 001 axis on the MgAl $_2$ O $_4$ films. The crystallinity and the lattice constant depended on the La content of the target. The dielectric constant of the PLZT film was measured with a metal-insulator-semiconductor(MIS) structure, and found to be 488 for the film deposited from the (10/65/35) target.

1.INTRODUCTION

Fabrication of epitaxial ferroelectric thin films on Si substrates would lead to the application of the films to various Si monolithic devices 1). We reported the epitaxial growth of PbTiO $_{3}$ on MgAl $_{2}$ O $_{4}$ /Si substrates in an earlier paper 2). The PLZT is also an attractive material because of its high dielectric constant, large electro-optic effect and so on. This paper reports the epitaxial growth of PLZT films on MgAl $_{2}$ O $_{4}$ /Si substrates.

2.EXPERIMENTAL

(001)MgAl $_2$ O $_4$ epitaxial films, 10C-100C Å thick, were grown on (001)Si (n-type) wafers by CVD technique in an Al-HCl-MgCl $_2$ -CO $_2$ -H $_2$ gas system at 98C°C. The PLZT films were deposited onto the substrates using a magnetron sputtering system under the conditions listed in Table 1. We used PLZT(\times /65/35) targets with varied La contents. The crystal structure and surface morphology of the films were investigated with X-ray diffraction, reflection high energy electron diffraction (RHEED) and scanning electron microscopy (SEM). The dielectric constant was measured with an Au-PLZT-MgAl $_2$ O $_4$ -Si metal-insulator- semiconductor (MIS) structure. The electrode was lmm x lmm in dimension.

3.RESULTS AND DISCUSSION

X-ray diffraction patterns for PLZT films yielded only (QQh)lines ,which indicates that the films grew along the QQl axis. Furthermore, we observed spot diffraction patterns in RHEED, as shown in Fig.1, for all the films. Therefore, we concluded that the PLZT films grew epitaxially along the QQl axis of the MgAl $_2$ Q $_4$ films. The La content of the PLZT x 65/35) tagets affected the films trystallinity and lattice constant, as shown in Figs.2 and 3,respectively. The prystallinity dependence on La content could be due to the lattice mitching between PLZT films and MgAl $_2$ Q $_4$ films. In the SEM study, columnar structures in cross sections of FLZT films and mosaic patterns on the surface of the films

were observed. Figure 4 shows a typical dapacitum e-virtage 2-1 during deasured at 1 MHz with a Au-PDZT-MgAIptg-Si-Au Ministructure. The dapacitumbe at the accomplation region in the 2-V curve of restricts to the lieuwith in average consisting of the PDZT layer and the MgAIpbq layer in series. The discretizing constant was estimated at 488 for the PDZT-1 45 pm films.

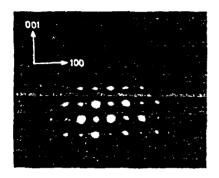


Fig.1. RHEED pattern of PLZT film

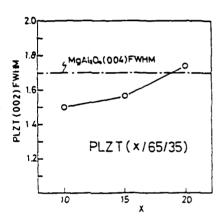
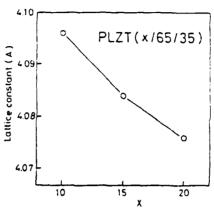


Fig. 2. Crystallinity of PLZT films as a function of La content (x), FWHM of the (OO2) X-ray rocking curve is considered a measure of film crystallinity.



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Fig. 3. Lattice constant of PLZT films as a function of La content (x).

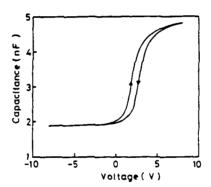


Fig. 4. Typical C+V curve of MIS structure measured at 1 MHz.

Table 1. Sputtering conditions for PLZT deposition

Substrate	(001 MgAl204. (001 Si
Target	PLZT(x 65,35)+5wt%Pb0
Substrate temp.	500 * 0
Sputtering gas	50% 02 ₃ 50% Ar
Pressure	2 x 10 ⁻⁴ terr
Input power	150 W.
Deposition rate	3500 Å/h

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SOME ELECTROOPTIC PROPERTIES OF PLET CERAMICS

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ABSTRACT: Dielectric and electrooptic properties were studied for the not-pressed lantanume modifed lead zirconate titanate(PL2T) ceramics near the composions of (9/67/33), where three phase boundaries were crossed. For the series with the composition of (9/2r/Ti), D-E hysteresis loop became slim and the quadratic electrooptic coefficients were decreased with increasing 2r/Ti ratio from (65/35) to (69/31).

1. INTRODUCTION

According to the phase diagram of PLZT established by Haertling and Land, 1) phase boundaries among two ferroelectric phases and a pseudo-cubic phase are crossed near the composition of (9/67/33), and near where the composition of (9/65/35), which is suitable for optical shutter applications, locates. However, the electrooptic properties have been scarcely studied around the crossed point, especially in both rhombohedral and pseudo-cubic phase. 1-3) The present study reports the dielectric and electrooptic properties in this region.

2. EXPERIMENTALS

2.1. Materials

Samples with various composition were prepared according to the general formula given by following equation (1).

$$Pb_{1-x}La_{x}(Zr_{y}Ti_{z})_{1-x/4}O_{3}$$
 (1)

where x and y were varied from 0.08 to 0.10 by 0.01, and from 0.65 to 0.69 by 0.02, respectively. PLZT ceramic powder was prepared from a mixture of Pb and La oxides with purity above 99.99% and Zr and Ti alkoxides, through hydrolysis. Prefired ceramic powder was hot-pressed by means of the two-stage method. 43 2.2. Measurements

D-E hysteresis loop was measured by applying AC electric field of 2kV/mm at 50Hz, used 5x5mm² by 0.25mm thick samples with silver electrodes on both surfaces. Birefringence (An) was determined from the retardation measured by a polarizing microscope with a Senarmom compensator, on a mirror-polished PLZT sample of 0.5mm thick with slit type electrodes separated by a gap of approximately 0.5mm on a surface. Quadratic electrooptic coefficient, R, was determined by following equation (2).¹⁾

$$R = (-2/n_1^3)(\overline{\Delta n}/E_3^2)$$
 (2)

where n_1 and E_3 were the refractive index and the aplied field, respectively.

3. RESULTS and DISCUSSION

Figure 1 shows the D-Z hysteresis loops for each composition illustrated on the PLZT phase diagram. In the system of (X/69/21), hysteresis loop changed to slim with increasing of La ratio, as reported in (X/65/35) system.¹⁾ On the other hand, in the system of (9/Y/2) with constant La ratio, the system

resis loops became slim with increasing Zr/Ti ratio from (65/35) to (69/31).

Figure 2 shows the birefringence as a function of electric field illustrated on the PLZT phase diagram. In the both systems of (X/05/35) and (X/69/31), memory effect was shown for La 8 atm%, and quadratic electrooptic effect was snown as La ratio was increased. In the system of (9/Y/2), quadratic curves changed to flat as 2r/Ti ratio was increased.

Table 1 summerizes the quadratic electrooptic coefficients calculated by eq.(2). In the system of (9/Y/Z), the quadratic electrooptic coefficient was increased with decreasing 2r/Ti ratio, and which was given as $1.2 \times 10^{-16} \mathrm{m}^2/\mathrm{V}^2$ for (9/67/33) and $2.0 \times 10^{-16} \mathrm{m}^2/\mathrm{V}^2$ for (9/65/35), respectively in tetragonal phase, however a little hysteresis was shown in birefringence. In pseudo-cubic phase, the quadratic electrooptic coefficient was smaller than that in tetragonal phase, in spite of

The difference between the experimental results and the refference data of quadratic electrooptic coefficient, for the composition of (9/65/35) and (10/65/35), was considered due to thickness of the samples, therefore further study should

be attempted for thinner samples.

smaller hysteresis.

TABLE 1. Quadratic electrooptic coefficient R $/(10^{-16} (m^2/v^2))$

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La	Zr/Ti ratio			
ratio	(69/31)(67/33) (65/35)			
9	0.13	1.2		(9.11 _b) ¹) (1.073) ¹)

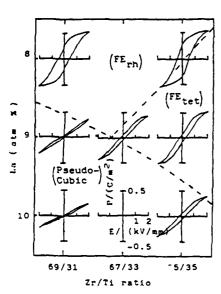


Fig. 1. D-E hysteresis loops measured at $25^{\circ}C$.

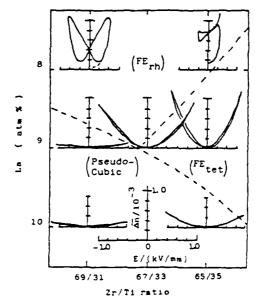


Fig. 2. Birefringence as a function of electric field at 25°C .

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T-21

DIELECTRIC PROPERTIES OF SPUTTERED POLYCRYSTALLINE (PL, La) (2r, T1) 03 THIN FILMS

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ABSTRACT: Thin films of polycrystalline $Pb_{1-x/100}^{La} x/100^{42} y/100^{71} z/100^{1} 1-x/400$ O_3 , PL2T, were prepared on a sapphire substrate by rf-magnetron sputtering from the PL2T sintered powder target. The sputtered films show a perovskite structure and exhibit a dielectric anomaly. Dielectric properties were discussed in comparison with bulk ceramics.

1. INTRODUCTION

Thin films of ferroelectric materials are of much interest for a fabrication of novel fuctional devices. The single crystal films of the quaternary solid solution of $Pb_{1-x/100}La_{x/100}(zr_{y/100}Ti_{z/100})_{1-x/400}^{0}$, PLZT(x,y,z), were extensively studied for making an electro-optic devices 1). Recently we have prepared polycrystalline thin films of the PLZT(x/y/z) by rf-magnetron sputtering and evaluated their dielectric properties.

2. PREPARATIONS AND MEASUREMENTS

The PLZT thin films were deposited by the sputtering from sintered PLZT powder target. The sputtering conditions are shown in TABLE 1. Sapphire wafers were used as the substrates. The substrate temperature was kept at 500 to 700°C. The dielectric properties of the sputtered PLZT films were evaluated in a sandwitch structure, Au thin film top electrode/sputtered PLZT films/TiN thin film base electrode, prepared on the sapphire wafers. The TiN base electrode was sputtered onto the sapphire wafer prior to the sputtering deposition of the PLZT films. The Au top electrode was deposited by a conventional vacuum deposition after the deposition of the PLZT films.

3. RESULTS AND DISCUSSIONS

The sputtered PLZT films showed a polycrystalline form with the perovskite structure. Their room temperature permittivity was ranged from 100 to 700 depending on their composition, and dielectric loss, $\tan\delta$ 0.01 to 0.1. The frequency dispersion of the permittivity was 5 to 15 % from the frequency range of 10 kHz to 1 MHz. These sputtered films exhibited a dielectric anomaly. Typical results for the PLZT films sputtered from PLZT(9/65/35) target are shown in Fig.1.

Figure 2 shows a variation of the dielectric properties with the La concentration in the target of PLZT(x/65/35). It is seen that the permittivity shows a maximum at the La concentration of about 10 %. This may suggest that there appears a phase change from rhombohedral/tetragonal/cubic by the increase of the La concentration similar to the case of bulk ceramics 2). The dielectricanomaly temperature observed in the sputtered films was 220 to 280°C which was higher than the dielectricanomaly temperature for bulk ceramics. This

is mainly due to the difference of the net composition between bulk ceramics and the sputtered films.

The sputtering process is generally believed to be the most reliable process for the deposition of the complex compounds. However, the difference of the chemical composition between the source target and the sputtered films must be taken into a consideration when the substrates are kept at the high temperature during the deposition. The effects of the stress and/or undissolved oxides on the dielectric properties should be also considered for the detailed discussions3).

TABLE 1. Sputtering conditions.

Target	PLIT powder, 1004
Substrate	Sapphire
Substrate temperature	500~700 °C
Sputtering gas	Ar(60%)+O; (40%)
Gas pressure	6.3x10 - ? Torr
Rf power	160 W
Deposition rate	70~100 A/min

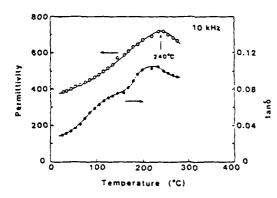


Fig. 1. Temperature dependence of dielectric properties.

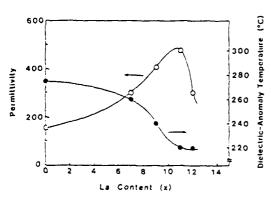


Fig. 2. Dielectric properties of PLZT thin films for various La contents.

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POSTER SESSION III

3

PREPARATION AND PERFORMANCE OF CERAMIC-AIR COMPOSITES FOR HYDROSTATIC SENSING

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ABSTRACT: Arrays of ordered, flat voids are introduced into PZT ceramic through the use of tape technology, by applying computer designed patterns of fugitive ink to green tapes. These are then stacked, laminated and fired. The resulting ceramic-air composites have modified mechanical properties and exhibit a greatly enhanced hydrostatic response.

1. INTRODUCTION

The hydrostatic sensing performance of lead zirconate titanate (PZT) with internal voids has been shown to be related to their lower Poisson's ratio of PZT ceramics with ordered voids.(1) The present work documents the preparation and piezoelectric behaviour.

2. EXPERIMENTAL

2.1 Sample Preparation

A screen is masked off with a pattern through which a fugitive ink is deposited onto green ceramic tape made from PZT 5A powder. These tapes are stacked and laminated under elevated pressures and temperatures. "Blanks" were made identically, except without fugitive ink. Upon burn-out, the organic constituents of the tape, and of the ink, vaporize and diffuse out, leaving voids where the ink had been. (2) At the subsequent sintering, the ceramic around these voids consolidates to a near fully dense state. Silver electrodes were then applied and the ceramics were poled at 130°C for 10 minutes in a silicon fluid.

2.2 Procedures for testing piezoelectric behaviour.

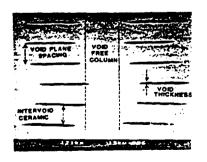
The uniaxial piezoelectric stress constant (d₃₃) was measured on a Berlincourt CPDT 3300 d₃₃ meter. An approximation of d₃₁ and d₃₂ was derived by using the d₃₃ probes with a thin insulator to apply stress onto 2 surfaces orthogonal to the electrodes, and connecting the 2 leads from the instrument to the silver electrodes. The resultant reading is multiplied by the ratio of the area touched by the instrument probes to the area of the silver electrodes. The free field acoustic response was measured in air and in oil by comparison with a calibrated pressure sensor.

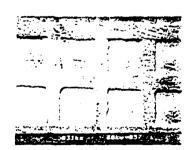
3. RESULTS AND DISCUSSION

3.1) Void shapes and volumes:

Figure 1 shows a crossection of a ceramic containing square shaped voids 0.5mil thick and

F:q. 2





limil long. Figures 2, 3 and 4 show ground top surfaces of samples with various void configurations. The porosities of these samples were 14.6% to 21.6%.

3.2) Piezoelectric Stress Coefficients and Dielectric Constants.

The day values increased with poling voltages up to 1.5 KV/mm. The table shows that after poling at 2.1 KV/mm the samples with void patterns had dag values that were 13% to 35% lower than those of blanks. There was some dispension in these day values. The (day+day)/day natios ranged from 0.19 in samples with disc shaped voids to -0.09 for some of the samples with the crossed bar shaped voids. This is compared to ~ -0.4 in blanks. The calculated d_h values are shown in Figure 5. They also increased initially with poling voltage. The unpoled dielectric constants of blanks were 1183. Those of the laminates with voids ranged from below 350 to above 550. Poling raised the dielectric constants of samples with voids only by about 9% to 38% instead of the 82% increase seen in blanks. One then calculates relatively high piezoelectric voltage sensitivities, gh. above 85 mVm/N. The measured free field hydrostatic responses were 20% less than those derived from the Berlincourt dgg data. They were within 3 db of their 1 KHZ value up to 100 KHZ. $d_h + gh$ products above 20 000 were calculated.

Samples with voids were encapsulated in a flexible epoxy. Preliminary tests indicate no change in hydrostatic sensitivity of these samples at pressures of 100 psi and no irreversible parameter changes under pressures in excess of 3000 psi.

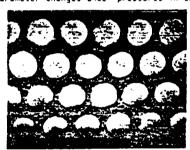


Fig. 3

Fig. 4

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400 FIGURE S PARALLEL BAR 044070 -0406 300-43,000 200đh (pC/N) 100 05 10 15 20 25 30 POLING VOLTAGE (KV/mm)

dh VERSUS POLING VOLTAGE

ACKNOWLEDGEMENTS

The support of this work by the Office of Naval Research and the performance of the free field measurements by C. Le Blank at NUSC and by W. Thompson at NRL are gratefully acknowledged.

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A RESONANCE TECHNIQUE FOR MEASURING THE COMPLEX ELASTIC, DIELECTRIC AND PIEZOELECTRIC COEFFICIENTS OF COMPOSITE MATERIALS

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ABSTRACT: Many composite piezoelectric transducers made from ceramics and polymers have quality factors $(\mathbf{Q_m} \text{ and } \mathbf{Q_e})$ far smaller than ceramics or single crystals. Moreover, the electromechanical coupling factors depend markedly on frequency, so that traditional measurement methods such as the IEEE standard, or the method recommended for ceramics by IEC, are not suitable for composites. Quasistatic measurements are also inadequate because they are too low in frequency.

In this paper, we describe two measurement techniques based on resonance methods. One experiment is for determining the real part of the electromechanical coupling factor appearing in the equivalent lumped circuit, and the other measures the complex coefficients through an analytical solution of a single resonant mode. These techniques have been applied successfully to single mode vibrations in low Q_m and low k^2Q_m piezoelectric materials. Results will be reported for NTK 0-3 composites, MRL fired composites, and pol-vinylidene fluoride films. An LF Impedance Analyzer (HP-4192A) and Computer (HP-9121) were used to process the data with iterative times of less than three minutes for the complex measurements.

The experimental results demonstrate that

- (1) The techniques are effective even for composites with $\Omega_{\rm m}<4$ and $k^2Q_{\rm m}\sim0.02$.
- (2) Errors in coupling factors can be reduced to less than 5% because the change in capacitance (C-C_O)/C can be measured very accurately. In this expression C is the capacitance of the sample, and C_O is the clamped capacitance.
- (3) Using a single disk-shaped sample, the real part of the electromechanical coupling factor can be obtained for the longitudinal length mode, the transverse length mode, the thickness mode, the planar mode, and the hydrostatic mode.
- (4) For NTK-306 composites and MRL fired composites, piezoelectric coefficient h_{33} is complex: h''/h' = 3.4% for the NTK sample, and -9.0% for the MRL composite. The assumption hat h_{33} is real for all piezoelectric materials must be reconsidered.
- (5) These techniques can also be applied to single-mode vibrations of low $Q_{\overline{m}}$ transducers even when the transducer is immersed in a liquid or attached to a solid. In this way, it is possible to estimate the effective coupling co-

efficient, efficiency, and bandwidth of the transducer near resonance

(6) Regarding the iterative method, we recommend using three frequencies: $f_1 = (1-0.2/Q_m)f_s$, $f_2 = (1+0.2/Q_m)f_s$, and $f_3 = (1+0.1/Q_m)f_s$. This choice is important for accurate measurements.

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- (7) These techniques work well for polyvinylidene fluoride films, but are unsuitable for piezoelectric ceramics with large $Q_{\rm m}$.
- (8) By altering sample size, the two methods can be used to measure coupling coefficients as a function of frequency and temperature.

FERROELECTRIC COMPOSITE TRANSDUCERS

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ABSTRACT: Ceramic/epoxy periodic composites (elastic superlattices) have important advantages over single phase ferroelectric ceramics in piezoelectric transducers for medical and NDE applications: (a) Lower acoustic impedance, (2) Higher piezoelectric coupling, (3) Suppression of lateral modes, (4) Reduction of crosstalk in imaging transducers. An overview is given of the theory of elastic superlattice vibrations needed to effectively exploit these features in the design of composite transducers.

1. INTRODUCTION

Piezoelectric composites, consisting of periodically arrayed ferroelectric ceramic inclusions in an epoxy matrix, were originally introduced for hydrophone applications¹⁾. These two-phase materials have better properties than those of either phase alone, leading to improved detection sensitivity. Piezoelectric composites are now finding applications in ultrasonic transducers, where they also provide improved performance²⁻⁷⁾. This paper explains the physical reasons for the improvements in transducer performance and gives general design rules for optimum transduction.

2. SUPERLATTICE STRUCTURE OF PIEZOELECTRIC COMPOSITES

A number of different periodic composite structures have been investigated^{1,5)}, but the standard, and most easily fabricated, form is a cross-diced ceramic with epoxy filling the saw cuts^{3,4)}. The elastic superlattice in this case consists of a square two-dimensional array of square ceramic rods in an epoxy matrix. It is a close-packed array, with the faces of each ceramic rod separated from its nearest neighbors by a small epoxy gap. The ceramic rod elements are poled along the length direction. Transducers are fabricated from composite plates, with the ceramic rods normal to the plate faces. Full face electrodes or electrode arrays are used, depending upon the application.

The transducers are designed to operate in the longitudinal thickness mode; but they can also vibrate in lateral resonances between the transducer edges. Such lateral resonances, when coupled piezoelectrically, interfere with the desired thickness mode and reduce its coupling. Lateral propagation in the transducer plate also causes mechanical crosstalk in imaging transducers. The superlattice structure of composite materials reduces these effects because, as in actual crystal lattices, wave propagation is impeded by stopbands for the lateral waves.

3. MODELING OF COMPOSITE TRANSDUCERS

A mathematical model has been constructed for elastic wave propagation in two-dimensional elastic superlattices and applied to the ceramic/epoxy composites used in transducers^{2,5)}. This model permits identification of the spurious lateral modes excited by the transducer and suggests methods for controlling them. It also predicts the widths, center frequencies and attenuation rates of the various superlattice stopbands. Because of the large impedance mismatch between the ceramic and epoxy phases, the stopbands are wide⁶⁾ and highly attenuating. Elastic damping can be incorporated into the model, and the effect of the thickness of the transducer plate can also be taken into account.

4. DESIGN CONSIDERATIONS

The superlattice model for lateral modes dictates a choice of superlattice period that is small compared with the plate thickness. As the transducer frequency is increased, this condition imposes more and more stringent fabrication tolerances. In this case, it is desirable to increase the period (i.e., to bring the spurious resonances closer to the main thickness mode), and a compromise must be made. Another condition is imposed on the choice of period by the need to trade-off the requirements for low acoustic impedance (matching into water) and optimum electro-mechanical coupling (insertion loss) 1. Current design approaches to these criteria are discussed in the references 3,4,7).

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PIEZOELECTRIC PROPERTIES OF SOME NEW HYDROPHONE MATERIALS

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ABSTRACT: The application of large-area hydrophones in passive sonar systems is an interesting new concept, and has been actively pursued since large sheets of polyvinylidene fluoride (PVDF) thick-films became available. However, it is known by now that PVDF is not adequate for this purpose because of several limitations, most notably its poor thermal stability, low dielectric constant and planar anisotropy. There is, therefore, an urgent need to seek for alternative transduction materials that can meet this new hydrophone requirement. The Underwater Sound Reference Detachment (USRD) of the U.S. Naval Research Laboratory has a continued effort in this endeavor. The results of recent studies on several new material systems will be reported in terms of their piezoelectric voltage coefficients g_h in hydrostatic mode: $g_h = dE_3/dp$, where E_3 is the electric field produced in the polar direction and p the pressure. The new materials include:

(1) VDF-TrFE Copolymers: The properties of copolymers of different compositions were measured as a function of pressure and aging temperature. DSC and X-ray studies were also carried out in order to better understand the effect of thermal treatment on their piezoelectric behaviors.

% VDF	T (°C)	K_{33}^{T}/K_{33}^{T} (initial)	g _h /g _h (initial)
70	85.0	1.07	C . 83
68	83.5	1.12	0.83
65.	83.5	1.32	0.51
70	92.0	1.18	0.59

(2) A "1-3" Piezoceramic Composite: The sample represented a recent successful development by the Plessey Australia Ltd. The design fashioned the basic concept of Newnham et al of the Pennsylvania State University. Initial samples were tested at USRD over a wide range of frequency and pressure.

p = 35 KPa				p = 7 MPa		
f (Hz)	C <u>(pf)</u>	D (**)	M* (dB)	C (pf)) (%)	М* (dB)
100	12920	2.6	-191.0	17254	2.6	-193.3
1000	12802	2.1	-191.7	16848	1.6	-193.9
2000	12708	2.1	-192.4	16754	1.7	-194.1

^{*} dB re 1 V/µPa

(3) Lead Titanate Ceramics: Samples of this new piezoelectric ceramic from three different sources have been studied, (see Fig. 1). Prototype hydrophones were designed to determine the frequency-domain response of this material. The low planar coupling of lead titanate is most interesting. The implication of this property on hydrophone applications is being investigated.

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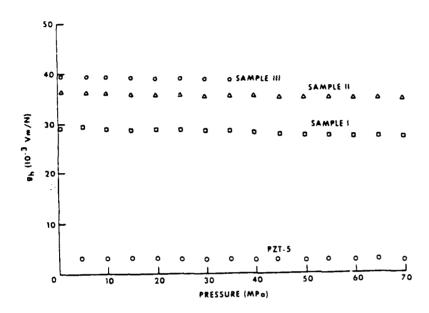


Fig. 1: Piezoelectric g_h coefficients for lead titanate samples as a function of pressure, compared with that of PZT-5.

(This work is supported by the U.S. Office of Naval Research).

DIRECTRIC AND PICKORICORIC PROPERTIES OF PBZ 05-PB (Zn4 5Nb2 5005 CLRAMCS

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ABSTRACT: The new piezoelectric ceramic materials of the PbZr $_{\rm X}$ (Zn $_1$ $_3$ Nb $_2$ $_3$ r $_{1-{\rm X}}$ 0 $_3$ system with compositions close to the antiferroelectric-reproelectric phase boundary have been studied. The antiferroelectric phase changes to the terroelectric phase at x-0.93 \sim 0.94. Piezoelectric properties are characterized by the large coupling factor of the thickness shear mode.

1. INTRODUCTION

The antiferroelectric phase in $PbZr0_3$ is very critical, in the sense that its free energy is very close to that of the ferroelectric phase, especially near the curie temperature 1 . Thus extensive research of $PbZr0_3$ -based compounds has been made from the standpoint of phase transitions $^{2+3}$. Recently, Takeuchi et al, found a large anisotropy in the electromechanical coupling factor of one $PbZr0_3$ -based ceramic 4 . In this work, we have attempted to obtain basic information regarding a new piezoceramic group, from an applicational viewpoint of electronic device material. The dielectric and piezoelectric properties of the $PbZr_X(Sn_1/3Nb2/3)_{1-x}0_3$ solid solution (abbreviated to "PZZN-100x") with up to 20 mol\$ $(Zn_1/3Nb2/3)$ were investigated.

2. EXPERIMENTAL METHODS

The specimens were made following the standard techniques of sintering: grinding, calcination at 800°C for 1 hour, milling and sintering at 1240°C for 1 hour in a PbO atmosphere using discs of pressed Pb₃2r₂0₇ powder. The curie point was determind from the temperature dependence of dielectric constant. Piezoelectric measurements are made by the resonance-antiresonance method.

3. RESULTS AND DISCUSSION

Remarkably high density samples with density ratios $92\sim00\%$ of theoretical X-ray density were obtained. X-ray powder diffraction patterns indicate a single phase of the perovskite structure.

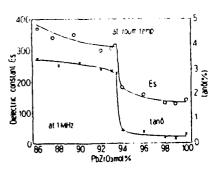
Figure 1 shows room-temperature values of fs and fs and fs and fs are properly system as a function of PbZr03 mol5. Both fs and fs are room temperature abruptly decreased at fs at fs and were almost independent of increasing PbZr03 mol5 fs in the range fs 0.94 to fs at room temperature exists near fs 0.93 fs 0.94.

Figure 2 gives the phase relation of the PZZN system determined from dielectric measurements and D-E hysteresis loop observations.

Typical values of the piezoelectric activities are given in Table 1. The piezoelectric constants were calculated from the coupling factor, the elastic compliance and the free permittivity. The relatively large anisotropy, κ_{33} , κ_{31} , as compared with that of PZI systems, has a maximum value of 4.5 at x=0.32.

being near the antiterroelectric to betroelectric (AF-F) phase boundary at room temperature.

The piezoelectric properties of the PZZN system are characterized by the low-tree permittivity, ξ_{11}^{-1} or ξ_{12}^{-1} , and the large coupling factor, χ_{15}^{-1} , of the thickness shear mode. The tree permittivity is one third of that of the conventional PZT system, and the coupling factor is two times as large as that of the Pb1103 system. These piezocciamic materials seem favorable for some applications such as ceramic tilters or resonators operated at high frequencies using the thickness shear mode.



200
200
200
Antiferroelectric

-50
00
98
96
94
92
90
88
86
Pb2(Osmolf %)

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Fig. 1 Dielectric constant ϵ_r and loss tangent $\tan\delta$ at room temperature of the PZZN system.

Fig. 2 The phase relation of the PZZN system.

Table 1 Piezoelectric properties of the PZZN-90 and PZZN-92.

	Table 1 Tiespercettie proportion of the					
	Dielectric-	Loss tang	Coupling factor	Frequency const.	Elastic compliance	Piezoelectric constant
	i const.	r ≁ent	kaa kai ki ko kis		Sit Sit Sit Sit Sit Sit Sit Sit	daa da1 d15 9aa 9a1 915
	10kHz	(%)	(%)	(Hz·m)	(10 ¹² m/N)	(1612CN) (163VmN)
PZZN-90		203 279	291 536	2090 2610 1520 2040 2710	743 198 741 810 740 14.	
PZZN-92		249 350		2090 2390 1560 2050 2780	7.73 205 7.70 133	402 157 349 809 173 459

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PIEZOELECTRIC PROPERTIES OF (Na.Li)NbO. CERAMICS

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ABSTRACT: The dielectric and piezoelectric properties of the solid-solution (Na,Li)Nb₃ have been studied. In this system with a small amount of alumina, high density, very fine microstructure and superior piezoelectric properties were obtained even by the ordinary sintering process. Using (Na_{0.0} Li_{0.1})NbO₃ solid-solutin with 0.5wt.X of alumina, ultrasonic transducers for high frequency up to 20MHz were developed.

1. INTRODUCTION

Polycrystalline piezoelectric materials in the application of ultrasonic transducers are based almost exclusively on PZT piezoelectric ceramics. For high frequency application, however, the fabrication of vibrating elements becomes difficult because of the small dimension required. Thus, another transducer materials which have the lower dielectric constant and higher sound velosity; are required. (Na,Li)Nb3 piezoelectric ceramics with lower dielectric constant and higher frequency constant is one of the candidates for such requirements, but it is well known that the dense body has not been obtained by the ordinary sintering process $^{1-3}$. Authors investigated on the effect of Al2 03 addition to (Na,Li)Nb0 3 ceramics to develop the transducer material for high frequency application.

2. EXPERIMENTAL

2.1. Sample Preparation

The raw materials used were sodium carbonate (99.5%), lithium carbonate (99.0%), niobium pentoxide (99.7%), and alumina (99.5%). The niobium pentoxide was commercial grade with 0.03% Ta_2 0s. For each composition, the raw materials were wet-mixed for 13 hrs in a nylon pot containing zirconia balls and ethanol, then dried and calcinated at 950 °C for 3 hrs in air. The calcinated powder was ball milled for 18 hrs using zirconia balls and pressed with PVA(2.5%) binder into tablets at 700 kg/cm². The tablets were sintered for 3 hrs at 1150-1240 °C in air. The sintered bodies were lapped to the desirable dimension and electroded by painting the body with silver paste , and then fired at 780 °C for 10 minutes.

2.2. Measurements

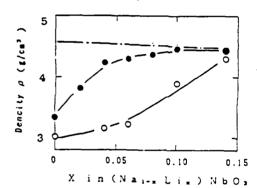
Samples for the microstructure analysis by the scanning electron microscopy (SEM) were prepared by polishing and thermal etching at $1050\,^{\circ}\mathrm{C}$ for 30 minutes. Densities of sintered bodies were determined using Archimedes' method. Specimen for piezoelectric and dielectric properties were poled in silicon oil at $1000\,^{\circ}\mathrm{C}$ for 0.5 hrs under a field of 5-6 kV/mm. More than 24 hrs after poling, the measurement was carried out by LF impedance analyzer(YHP:4192A).

3. RESULTS

Figl. shows the density of (Na $_{1-x}$ Lix)NbO3 ceramics as a function of the lithium content X. Measured densities are too small compared with theoretical values deviated from the X-ray diffraction analysis. The microstructure of (Na o. $_{1}$ Lio. $_{1}$)NbO3 ceramics containing 0.5 vt.X alumina is shown in Fig.2a. Fig.2b shows the microstructure of alumina free (Nao. $_{2}$ Lio. $_{1}$)NbO3 ceramics. Piezoelectric and dielectric properties of (Na o. $_{2}$ Lio. $_{1}$)NbO3 vith 0.5 vtX alumina are listed in Table 1. Electron microscopy revealed that a small amount of alumina addition enhanced the sinterability without the large grain growth and the superior piczoelectric properties of (Na,Li)NbO3 ceramics were obtained. Using (Nao. $_{2}$ Lio. $_{1}$)NbO3 vith 0.5 vt.X Al2 O3 ,ultasonic transducers from 5 MHz up to 20 MHz have been developed.

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+ 0.5 vt.% Al 2 02 .

properties of (Nao. + Lio. 1)NbOs

Dielectric Constant

 $\varepsilon_{33}/\varepsilon_{\alpha} = 110$ (1kHz)

Table.1. Piezoelectric and dielectric

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7

Coupling Factor Kt= 42 %

Kp= 21

Frequency Constant Nt= 2900 Hz-m

Np= 3700

Density $\rho = 4.5 \times 10^3 \text{ kg/m}^3$

Curse Temperature Tc= 340 °C

Fig.1. Measured density of $(Na_{1-x}|L_{1:x})NbO_3$ as a function of lithium content X.;

O : without alumina, . : with 0.5 vt.X alumina,

-- : theoretical value.

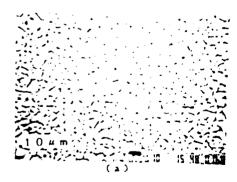




Fig. 2. SEM photographs of (Na o. + Lio.) NbO3 ceramics with 0.5 vtX Al2 O3 (a) and without Ai2 O3 (b).

ELECTROMECHANICAL PROPERTIES OF PLANAR VIBRATIONAL MODE IN PZT POLYMER PIEZO-ELECTRIC COMPOSITES

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ABSTRACT: Electromechanical properties of planar vibrational mode in PZT 'polymer 1~3 composites were determined as a function of the PZT volume fraction and PZT pillar shape. An electromechanical coupling factor $\mathbf{k}_{\mathbf{p}}$ of 0.38 was observed when using epoxy as a polymer matrix.

1. INTRODUCTION

Recently, piezoelectric composites(PZT/polymer) having various structures have been intensively analyzed for hydrophone and medical ultrasonic probe applications. These composites can be classified according to Newhham's connectivity theory. The 1-3 connectivity(PZT pillar embedded in a polymer matrix) is reported to be useful for high-frequency medical ultrasonic applications. Furthermore, the dynamical behavior of the thickness mode has been analyzed theoretically in the 1-3 composites.

However, the planar vibrational mode of 1-3 composite has not yet been investigated systematically because this mode is unwanted vibration for medical ultrasonic application. In the present work, electromechanical properties of planar vibrational mode were determined as a function of the P2T volume fraction and P2T pillar shape.

2. EXPERIMENTAL

PZT/polymer 1-3 composite disks were fabricated using a "dicing and filling" technique. The PZT pillar size and volume fraction were varied by changing the blade thickness and dicing pitch. Chromium-gold films were deposited as electrodes onto both surfaces of composite disks.

The electromechanical properties of planar vibrational mode were determined by measuring the impedance characteristics with an HP-4192A impedance analyzer. The electromechanical coupling factor $k_{\rm p}$ was determined from the following equation:

$$k_p^2 = 1.24 \frac{f_n^2 - f_m^2}{f_n f_m}$$

where f_m is the minimum-impedance-frequency, and f_n the maximum-impedance-frequency. Frequency constant N_D was approximated by

$$N_0 + f_m a$$
 (a: diameter of disk)

3. RESULTS AND DISCUSSION

Typical impedance characteristics of PZT epoxy composite disk are shown in Fig.1 together with phase characteristics. Here, the diameter and the thickness of the disk are ilmm and 0.4mm, respectively. A single resonant curve was obtained.

Frequency constant N_p and directromechanical coupling factor k_p are shown in Fig.2 as a function of FZT volume fraction $\kappa_{\rm EMT}$. Sample thickness is 0 imm and FZT pillar shape wit is changed from 1 to 3. Frequency constant was found to be clearly dependent on $\gamma_{\rm EMT}$. This is because the planar vibrational mode is exited through direct mechanical interaction between FZT pillar and polymer matrix.

Electromechanical coupling factor k_p gradually decreased with a decrease in v . However, the value of κ_p stayed as high as $0.32{\sim}0.38$ over the region $v_{p27} \sim 0.25{\sim}0.7$ when using epoxy as a polymer matrix. This is large enough for lateral mode applications

The results of this work imply that PZT epoxy i-3 composites are potential materials for not only thickness mode application but also flexture mode application such as a piezoelectric speaker. In addition, low acoustic impedance compared to PZT, relatively high $\kappa_{\rm p}$, and flexibility of these materials may also open the way to other new applications.

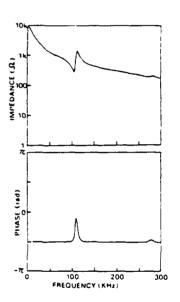


Fig. 1. Impedance and phase characteristics of PZT/epoxy composite disk (diameter: llmm, thickness: 0.4mm). PZT volume fraction and PZT pillar shape w/t are 0.59 and 1.0, respectively.

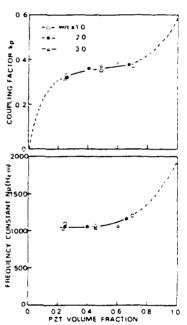


Fig. 2. Frequency constant and electromechanical coupling factor of planar vibrational mode in composite disk as a function of PZT volume fraction (sample thickness: 0.1mm).

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Anisotropic Piezoelectric Coupling Factor of [Pb x(Bim...Nam...)] TiO, Ceramics

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Alkaline earth metals (Ba,Sr,Ca) or rare earths (La,Pr,Nd,Em,Gd) modified PbTiO, ceramics have been extensively investigated because of their great promise as a material for high frequency and high temperature applications, and it was found that Ca or Sm with smaller ionic radius compared with Pb ion was excellent as the substituting elements to make large piezoelectric anisotropy between longitudinal and transverse modes. Sakata et al investigated the piezoelectric properties of $(Bi_0...,Na_0...)$ TiO₂-PbTiO₃ system near the MPB compositions. (3, 2), 2) In the tetragonal phase rigion of their system, large anisotropy in piezoelectric properties would be expected because of the small ionic radius of Bi and Na ion. In this study, dielectric and piezoelectric properties of PbTiO₃-(Bi_{0...}Na_{0...}) TiO₃-Pb(Fe_{0...}Nb_{0...})O₃ system ceramics were experimentally investigated. The compositions of the ternary system were x-PbTiO₃-y-(Bi_{0...}Na_{0...})TiO₃-z-Pb(Fe_{0...}Nb_{0...})O₃ with 1 mol% MnCO₃ (hereafter abbreviated to PBFNx/y/z).

Lattice parameters of the PBFN (x/y/0) and PBFN (x/y/5) as a function of PbTiO₃ content (x) are shown in Fig.1. MPB was found near x=18 mol% in PBFN (x/y/0) as same as reported by Sakata. By adding of 5mol% Pb $(Fe_0...,Nb_0...,0)$ O₃, tetragonal phase region was extended, moreover the change of

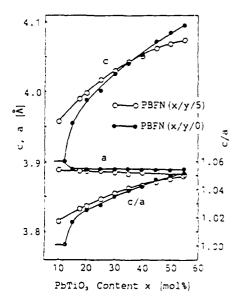
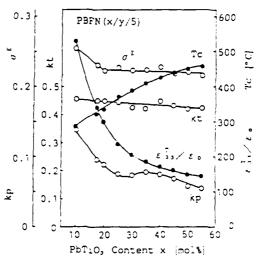


Fig. 1. Lattice parameters of the PBFN(x/y/0) and PBFN(x/y/5) as a function of PbTiO, content(x).



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Fig. 2. Electromechanical coupling factor kp,kt, dielectric constant $\varepsilon_{30}^{-1}/\varepsilon_{00}$, Curie point Tc and poisson's ratio σ^{ε} of PBFN (x/y/5).

crystal tetragonality (c/a) was decreased. Figure 2 shows electromechanical coupling factor kp,kt, dielectric constant $e^{\frac{\pi}{4}}$,/e, Curie point To and poisson's ratio σ^{\pm} of PBFN(x/y/5) as a function of $\langle x \rangle$. Thickness dilatational coupling factor kt did not noticeably change with PbTiO, content (x) and had relatively large values (0.42-0.46). In contrast to kt, planar coupling factor kp decreased notably in the region from x = 10 to x = 25, and kept the values (0.072-0.078) from x = 25 to x = 40, and decreased again in the region greater than x = 45. Poisson's ratio σ^* decreased from x = 10 to x = 20, and kept the value (0.22) in the region greater than x = 0.20. This change is similar to that of kp. this result suggests that anisotropy of coupling factor relates to poisson's ratio σ^{E} . The $\varepsilon_{3,1}^{S}/\varepsilon_{0}$ decreased rapidly with $-\infty$ and Tc increased to correspond to c/a change, $\epsilon_{13}^{2}/\epsilon_{0}$ was smaller than 200 and Tc was higher than 400° C in the region greater than x = 30. Figure 3 shows coupling factors kt,kp of PBFN(x/y/0) and PBFN(x/y/5). By substituting 5 mol% Pb(Feo., Nbo.,)O,, kp decreased remarkably in the PbTiO, rich region. Figure 4 shows the correlation between $\sigma^{\mathtt{f}}$ and coupling factor Kp which have reported in the various kinds of PbTiO, ceramics. Good correlation between kp and σ^{i} can be seen, and it suggests that kp has negligibly small value if $\sigma^{\rm E}$ is smaller than 0.19. However, it is not enough to explain this relation theoretically because $\sigma^{E} = s_{12}^{E}/s_{11}^{E}$ is not an intrinsic constant to dominate kp value.

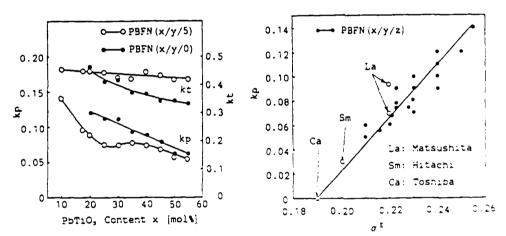


Fig. 3. Effect of substitution of 5 mol% Pb(Fe.., Nb..,) O, on coupling factors kp, kt of PBFN (x/y/0).

Fig. 4. Correlation between σ^{\pm} and coupling factor kp in PbTiO, ceramics modified with various substituting elements.

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EFFECTS OF SHAPE AND VOLUME FRACTION OF CLOSED PORE ON DIFLECTRIC LOSS, MECHANICAL QUALITY FACTOR AND ELECTROMECHANICAL COUPLING FACTOR OF DIFLECTRIC AND PIEZOELECTRIC CERAMICS

- A THEORETICAL APPROACH -

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1. THEORY

Series and parallel models are schematically shown in Fig.1. Elustic properties for shear modulus G and bulk modulus K are expressed as follows: For series model.

$$1/\overline{G} = {}^{1}v/{}^{1}G + {}^{2}v/{}^{2}G + (1) \qquad 1/\overline{K} = {}^{1}v/{}^{1}K + {}^{2}v/{}^{2}K$$
 (2)

for parallel model.

$$\overline{C} = {}^{\dagger}v \cdot {}^{\dagger}G + {}^{2}v \cdot {}^{2}G$$
 (3) and $\overline{K} = {}^{\dagger}v \cdot {}^{\dagger}K + {}^{2}v \cdot {}^{2}K$. (4)

Young's modulus E and Poisson's ratio σ are expressed as a function of G and K as follows: E = 9KG/(3K+G) ····· (5) and $\sigma = (3K-2G)/(2(3K+G))$. (6)

Combining the equations 1-6, one can obtain the equations for the Young's modulus and Poisson's ratio as follows: For series model,

$$1/\bar{E} = {}^{t}v/{}^{t}E + {}^{z}v/{}^{z}E$$
 (7) and $\bar{\sigma} = ({}^{t}v/{}^{t}E) \cdot {}^{t}\sigma + ({}^{z}v/{}^{z}E) \cdot {}^{z}\sigma$. (8)

For parallel model, Hashin discussed the elastic properties of fiber-reinforced composite and gave a very important approximation as follows: 1)

$$\overline{E} \approx^{1} v \cdot {}^{1}E + {}^{2}v \cdot {}^{2}E + {}^{2}(9) \quad \text{and} \quad \overline{\sigma} \sim {}^{1}v \cdot {}^{1}\sigma + {}^{2}v \cdot {}^{2}\sigma \qquad (10)$$

where Poisson's ratio σ is with less accuracy. It is the equations 7 and 9 for the Young's modulus that Newnham et al. based on when he derived those for piezoelectric constants of the series and parallel models. 23

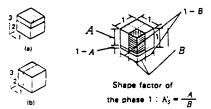


Fig.1. (a) Series and Fig.2. Modified (b) parallel models. cubes model.

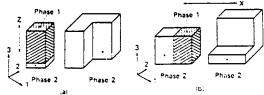


Fig. 3. Schematic representation of the model which is divided is into two parts for (a) Z and (b) X directions.

where s' and s' are real and imaginary parts of complex elastic compliance s (=s'-j·s'). Combining the equations 7, 9 and 11, the theoretical equations for G_n or $\tan \delta_n$ of series and parallel models are obtained as follows:

For Q_{m23} or $\tan\delta_{m23}$ of series model and Q_{m11} or $\tan\delta_{m11}$ of parallel model, and

$$1/\overline{Q}_{n} = \overline{\tan \delta}_{n} = \frac{-i v \cdot i s \cdot i \tan \delta_{n} + \frac{z}{v} \cdot z s \cdot z \tan \delta_{n}}{i v \cdot i s + \frac{z}{v} \cdot z s}$$
(12)

for Q_{m11} or $\tan\delta_{m11}$ of series model and Q_{m33} or $\tan\delta_{m33}$ of parallel model in the case when $(1 \tan\delta_m)^2 < 1$ and $(2 \tan\delta_m)^2 < 1$.

$$1/\overline{Q}_{n} = \frac{1}{\tan \delta_{n}} = \frac{1 \cdot v + 2s + 1 \tan \delta_{n} + 2v + 1s + 2 \tan \delta_{n}}{1 \cdot v + 2s + 2v + 1s}$$
(13)

Dielectric loss tangent is defined as follows:

$$\tan \delta = \epsilon^*/\epsilon^* \tag{14}$$

where ϵ ' and ϵ " are real and imaginary parts of complex dielectric constant $\hat{\epsilon}$ (= ϵ ' - j · ϵ '). This relation and the equations of dielectric constants from series and parallel models are similar to the elastic compliance's.

Accordingly one obtains the following equations:

For $\tan \delta_{33}$ of series model and $\tan \delta_{11}$ of parallel model.

$$\frac{1}{\tan \delta} = 1/\overline{Q} = \frac{(v + (\epsilon + (\tan \delta + (2v + \epsilon + 2\tan \delta))))}{(v + (\epsilon + (2v + 2\epsilon)))}$$
(15)

and for $\tan \delta_{11}$ of series model and $\tan \delta_{12}$ of parallel model in the case when $(\tan \delta)^2$

$$<<1$$
 and $(2 \tan \delta)^2 <<1$,

$$\frac{1}{\tan \delta} = 1/\overline{Q} = \frac{(v + 2\varepsilon + 1\tan \delta + 2v + 1\varepsilon + 2\tan \delta)}{(v + 2\varepsilon + 2v + 1\varepsilon)}$$
(16)

Assuming that the unit cell of the modified cubes model (Fig.2) is divided into two parts as shown in Fig. 3 (a) for Z axis direction and (b) for X axis direction respectively and based on this geometry and combining theoretical equations from series and parallel models, one can derive the theory on the dielectic, clastic and electromechanical properties. The notation is used in this paper according to Newsham's, 21

With consideration of distribution and shape of pores (shape factor $K_{S})^{(3)}$ and assuming that 'F = 0 and ' $\sigma = 0$, the theoretical equations for Young's modulus \overline{E} , elastic compliance \overline{S} and Poisson's ratio of the ceramics with closed pures are obtained as follows:

$$\overline{E}_{13} - 1/\overline{s}_{33} = {}^{2}E_{3\downarrow}(1 - P^{2/3}/K_{5}^{2/3}) = (1/{}^{2}S_{13})(1 - P^{2/3}/K_{5}^{2/3})$$
(17)

$$\overline{\sigma}_{31} = {}^{2}\sigma_{31} (1 - \rho^{2/3}/K_{5}^{2/3})
\overline{E}_{11} = 1/\overline{S}_{11} = {}^{2}E_{11} (1 - \rho^{2/3}, K_{5}^{1/3}) = (1/{}^{2}S_{11}) (1 - \rho^{2/3}, K_{5}^{1/3})$$
(18)

$$\frac{E_{11} = 1/S_{11} = e_{11}(1 - P^{2/3}/K_5^{1/3}) = (1/2S_{11})(1 - P^{2/3}/K_5^{1/3})}{\sigma_{12} = 2\sigma_{12}(1 - P^{2/3}/K_5^{1/3})}.$$
(20)

and

Theoretical equations for mechanical quality factors Qm., and Qm., or mechanical loss tangent $\tan \delta_{min}$ and $\tan \delta_{max}$ of the ceramics with closed pores are obtained as follows:

$$\overline{Q_{n+1}} = 1/(\tan \delta_{n+1}) = 1/(\tan \delta_{n+1}) = 2Q_{n+1}$$
(21)
$$\overline{Q_{n+1}} = 1/(\tan \delta_{n+1}) = 1/(\tan \delta_{n+1}) = 2Q_{n+1}$$
(22)

Theoretical equations for dielectric loss tangent $an \delta$ from series and parallel models are derived as equations 15 and 16. Assuming that the loss tangent of pore 'tan's is zero. the dielectric loss tangent of the ceramics with closed pores are obtained as follows:

$$\overline{\tan \delta_{33}} = z \tan \delta_{33} \qquad (23) \quad \text{and} \quad \overline{\tan \delta_{11}} = z \tan \delta_{11}. \tag{24}$$

The radial coupling factor $k_{\mathfrak{p}}$ is expressed as follows:

$$k_{r}^{z} = \frac{2 \cdot d_{si}^{z}}{\varepsilon_{si}^{z} \cdot s_{ii}^{z}} \frac{1}{(1 - \sigma_{is}^{z})} \qquad (25)$$

75

5.53

 $\overline{}$

As \overline{k}_{\bullet} is a function of $\overline{\epsilon}_{33}^{\dagger}$, \overline{d}_{31} , $\overline{s}_{11}^{\epsilon}$ and $\overline{\sigma}_{12}^{\epsilon}$, one can obtain a theoretical equation for \overline{k}_p as a function of volume fraction (P) and shape factor (K_s) of pores.

2. RESULTS AND DISCUSSIONS

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Okazaki et al. have reported peroxity dependences of resonant impedances $(2_{\mathfrak{p}})$ and radial coupling factors (kg) of hot pressed pieznelectric (P2T) ceramics. 4 Comparisons between theory and experimental results are shown in Fig.4 (a) and (b).

Bunno et al. have investigated the purosity dependences of dielectric loss tangent (tan &) or electrical quality factor (Q=1/tan δ) of microwave dielectric ceramics. Results are shown in Fig. 5. 5 There is no dependence of the quality factor (Q) on porosity, which agrees well with the theoretical equations 21 and 22.

In Fig. 3, the theoretical values agree well with the experimental ones in the case when the Ks value is 0.5. This results are same as those for dielectric and piezoelectric constants. 33

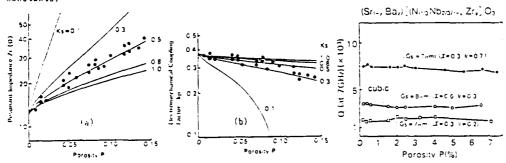


Fig. 4. Comparison between the experimental and theoretical Fig. 5. Electrical quality factor values for (a) resonant impedance 2, and (b) electrog(=1/tan 0) of microwave dimechanical coupling factor k, of hot pressed P2T. electric ceramics vs. porosity

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EFFICIENCY OF PIEZOELECTRIC CERAMIC ACTUATOR

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ABSTRACT: Multilayer pieznelectric ceramic actuator efficiency for pulse mode operation was experimentally investigated. About 60 % of supplied electrical energy could be recovered for the actuator without mechanical loading, using a dc source with a series inductor. About 20 % of the supplied energy was lost in the actuator as heat.

1. INTRODUCTION

In order to operate the multilayer piezoelectric ceramic actuator 1) in a pulse mode, a charge-discharge circuit has conventionally been used. In this case, unused stored energy in the actuator was wasted in every discharge cycle. The present study reports a method to recover the unused stored energy.

2. BASIC PRINCIPLE

Figure 1(a) shows a driver circuit with a series inductor L. When switch switch on, voltage across the actuator $V_{\rm C}$ and current I change with a time, as shown in Figs.1(b) and (c), respectively. The actuator is charged during the first half cycle (0 \leq t < T/2). The amount of energy supplied from an electrical source $E_{\rm S}$ can be expressed as

$$\varepsilon_{s} = \varepsilon_{o} \int_{0}^{T/2} 1 \, dt \tag{1}$$

where E_0 is the dc source voltage. In the second half cycle $(7/2 \le t \le T)$, unused stored energy in the actuator can be recovered. The amount of recovered energy $\hat{\epsilon}_{-}$ is expressed as

$$\varepsilon_r = \varepsilon_0 \int_{T/2}^{T} |I| dt \tag{2}$$

3. RESULTS AND DISCUSSION

Current I was measured for an actuator without mechanical loading, using the driver circuit as shown in Fig.1(a), where $\rm E_0=78~V$ and $\rm L\approx10~mH$. The result is shown in Fig.2. Pertinent values for $\rm E_S$ and $\rm E_r$ are 2.7 mJ and 1.5 mJ, respectively. Fifty six percent of supplied energy is recovered.

The sum of equivalent resistances, for the inductor and the actuator ${\rm R_L} + {\rm R_C}$, is determined by

$$R_{L} + R_{c} = (2L/7)\ln(I_{1}/I_{3}) \tag{3}$$

where $R_{i} = 10 \Omega$.

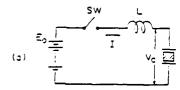
Consequently, the heat energy lost in the actuator in one cycle $\boldsymbol{\xi}_{\perp}$ can be calculated by

$$c_{L} = R_{c} \int_{c}^{T} z^{2} dt \tag{4}$$

The value is 0.58 mJ, corresponding to 21 $^\circ$ of the supplied energy. Actuator temperature Δ T can be expressed as

$$\Delta T = E_{i} \cdot f \cdot t_{i} \cdot m \cdot c \tag{5}$$

where f is repeated frequency,t is voltage application duration time,c is specific heat and m is mass. Figure 3 shows observed and calculated temperature rise ΔT values.



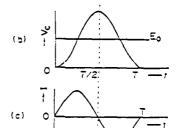


Fig.1. Actuator driving circuit with an inductor (a) circuit (b) voltage across the actuator (c) current.

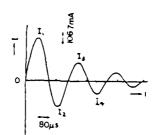


Fig.2. Observed current I with $E_0 = 78~\text{V}$ and L = 10 mH.

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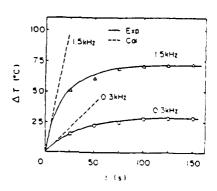


Fig.3. Actuator temperature rise Δ 7 during pulse driving.

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CERAMIC GREEN SHEET PUNCHER USING PIEZOELECTRIC ACTUATOR

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ABSTRACT: A Ceramic Green Sheet is required to have many through holes, made by a small hole punching tool with a very small pitch. A Ceramic Green Sheet Puncher generally has a punch and die arranged in some pattern. However, a puncher which has patterned punch die, can not be used to match a variable pattern. The authors have developed a ceramic green sheet puncher, using a piezo electric actuator. It is compact and can punch through holes in a variable pattern.

MECHANICAL STRUCTURE

This ceramic green sheet puncher uses a piezoelectric actuator which takes advantage of the momentary stretch force in a piezoelectric actuator. This stretching force actuates a pin, the punch, in such a manner as to punch a through nole in a ceramic green sheet, placed between die and punch. The pin, the punch, is mounted at the center of the plate spring. Moved by the force from piezoelectric actuator, the spring is bent, the pin is moved forward until it enters the hole in the die through the ceramic green sheet. The puncher has two lines of pins drawn up in a line. Each line has 30 pins. The puncher moves laterally and ceramic green sheet moves at a right angle to the puncher. The piezoelectric actuator is driven according to instructions from the control instrument. Movements are made according to a pattern which is shown on the CRT.

ABILITY

This ceramic green sheet puncher, using a piezoelectric actuator, can punch 2400 through holes in a ceramic green sheet during a 90 second time period including the green sheet. The inner diameter of the through hole is 0.251 mm, when the ceramic green sheet is punched with a 0.250 mm diameter pin. The die has a 0.350 mm inner diameter. Sometimes the back of the ceramic green sheet breaks off putting a burn on the inner edge of the through hole. That burn causes no trouble in regard to using the punched hole as a through hole. The distance the hin moves is 1 mm, when 120 V is applied to the piezoelectric actuator and when a place spring, 0.05 mm thick and 3 mm wide, is used the through hole pitch is 1.295 mm and pitch error is ±0.02 mm. The puncher and ceramic green sheet feeder has 0.005 mm resolution. This equipment can punch holes in an 83 mm×83 mm area and 100 mm×100 mm ceramic green sheets can be mounted in the punch press.

MONOMORPH ACTUATORS USING SEMICONDUCTIVE FERRUELECTRICS

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A new actuator device is proposed using semiconductive ferroelectric ceramics. This device is a simple-plate actuator capable of bending equivalently to a piezoelectric bimo.nh. A significant difference is a simple structure named as a "monomorph in comparison with a multi-stacked type in the bimorph, as illustrated in Fig. 1.

The key to obtaining the bond in the monomorph device is to realize non-uniform electric field distribution in the piezoelectric ceramics. If the ceramic plate is semiconductive as well, the ceramics-metallic electrode junction introduces a partier to the electron energy band structure (Fig. 2(a)). When an electric voltage is applied to the semiconductive plate through the electrodes, the field is concentrated only on one side of the plate, as shown in Fig. 2(b). The commination of the piezoelectricity with the field non-uniformity causes the bend in the ceramic plate.

Figure 3 shows examples of monomorph actuators:(a) $0.8\text{PbZrO}_3 - 0.2(K_{1/2}Bi_{1/2})$ 2rO_3 -1 mol&Al $_2\text{O}_3$ (20mm x 10mm x 0.5mm) and (b) $8\text{aTiO}_3 - 0.18$ mol&Dy $_2\text{O}_3$ (40mm x 10mm x 0.5mm). The displacement at the top of a monomorph reaches 100 um, comparable to the deflection of the conventional bimorphs. The slope of the displacement curve suggests the semiconductive characteristics, n- and p-type, for the samples (a) and (b), respectively. It is worth to note that the ceramic plate with ormic-contact electrodes (InGa) reveals no significant deflection.

Figure 4 shows the composition dependence of the monomorph characteristics in the solid solution ceramics (1-x)Pb2rO $_3$ -x(K, $_{12}$ Bi, $_2$)2rO $_3$ (20mm x 10mm x 0.65mm). The dopants such as Al $_2$ O $_3$ and SiO $_2$ also affect significantly to the properties.

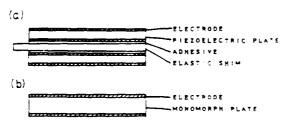


Fig. : Structures of a pimorph of and a monomorph actuator (b).

The electromechanical resonance can be observed in most of the monomorphs, as demonstrated in Fig. 5 for the PbZrO3-based plate: This indicates that the new monomorph actuators are applicable to buzzers, speakers, third purps etc., replacing the conventional piezoelectric bimorphs.

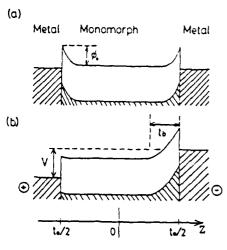


Fig. 2 Energy barrier model for a monomorph device.

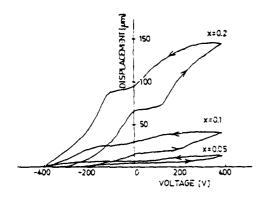


Fig. 4. Composition dependence of monomorph characteristics in the PbZrO $_3$ - ($K_{1/2}B\iota_{1/2})\iota_{2}ro_{3}$ ceramics.

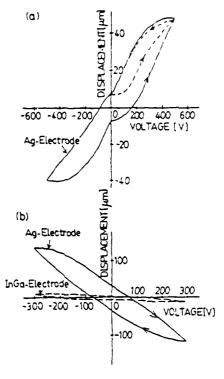


Fig. 3 Monomorph characteristics in (a) lead zirconate based and (b) barium titanate based ceramics.

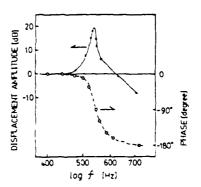


Fig. 5 Electromechanical resonance in a Pb2r03-based monomorph actuator.

DEVELOPMENT OF FLECTROSTRICTIVE CERAMICS

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ABSTRACT: Electrostrictive ceramics with a large displacement (strain) for the piezoelectric actuators have been developed. As large strain as 1×10^{3} which is induced transversely to the applied electric field is obtained at 10 kV/cm by using electrically induced phase transitions between ferroelectric (FE) phase and antiferroelectric (AFE) one in FE-AFE coexisting ceramics.

1. INTRODUCTION

The recent developments 1,2) of the piezoelectric ceramics have opened the piezoelectric actuators with relatively large stroke, fast responce and compact size. For these applications, the easy generations of a large stroke under low applied voltage are essential. This requirement has been partially satisfied by the use of multilayer structure 3), but improvement of material properties is also necessary. The present study reports the electrostrictive ceramics with a large strain.

2. EXPERIMENTAL AND RESULTS

Four types of mechanism for the piezoelectric strains are now known, that is, (1) usual plezoelectric strain propotional to piezoelectric strain constant d, (2) domain reorientation, (3) volume change accompanied with phase transitions, and (4) electrostriction. In order to obtain a large strain, above four types of strains should be fully utilized. In the present work, it was clarified that a large strain can be achieved using electrically induced phase transitions in the FE-AFE phases coexisting cermics as shown in Fig.1. For example, the transverse strain such as 1×10^{-3} , normal to the applied electric field, is obtained at 10 kV/cm. It is necessary to improve several properties of this ceramic material, such as large hysteresis and temperature stability, in the case of some applications.

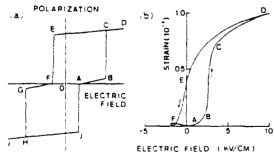


Fig.1 (a) Schematic doublehysteresis loop of a FE-AFE coexisting ceramics. Regions of G-F-O-A-B show AFE state and D-C-E and I-H-J show FE ones.(b) Strain vs. applied electric field curve of (Pb, Sr)(Zn,Ni,Nb)O, ceramic material.

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TEMPERATURE DEPENDENCE OF ELECTROSTRICTION UNDER A HIGH ELECTRIC FIRM

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ABSTRACT: A multilayer actuator, using a modified lead zinc niopate ceramic, was fabricated to investigate the temperature dependence of electrostriction under a high electric field. Temperature dependence of electrostriction under a high electric field was estimated to be less than 1.2%/°C by using dielectric stiffness, higher order stiffness and their temperature derivatives.

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1. INTRODUCTION

The electrostrictive effect is suitable for micropositioner applications, because of small strain hysteresis¹⁾. However, one of the problems for electrostrictive materials is temperature dependence of strain. Since the electrostrictive coefficient Q does not change much with temperature fluctuation 2-4), the change in dielectric properties should be the main cause for temperature dependence of strain.

2. TEMPERATURE COEFFICIENT OF ELECTROSTRICTION

The relation between electric field E and polarization P can be approximately expressed as

$$\Xi = \propto P + \delta P^3 + rP^5 \tag{1}$$

where α , β and r are dielectric stiffness and higher order stiffness. The relation between electrostriction S and polarization P is expressed as

$$S = \mathbb{Q}P^{2}$$

where Q is the electrostrictive coefficient. Under a constant electric field (dE = 0), the temperature coefficient of electrostriction is given by the following equation, derived from Eps. (1) and (2).

$$\frac{1}{5}\frac{dS}{dt} = \frac{1}{C}\frac{2Q}{dt} - \frac{2}{\sigma + 2QP^2 + 5P^2 + \sigma^2} + \frac{2\sigma}{\sigma T} + \frac{2\sigma^2}{\sigma^2}.$$
(3)

3. EXPERIMENTAL

A multilayer deramic electrostrictor was fabricated by the conventional green sheet method for easy electric field application. A modified lead zinc miopate deramic was used for the electrostrictive material, and Ag-Pd was used for the internal electrodes. Hysteresis curves for electric field vs. polarization were recorded with a Sawyer-Tower directly under various temperature, from 9°C to 32°C.

4. RESULTS AND DISCUSSION

From the hysteresis curves, $x_{i,j}$ and i were calculated by the least square

method. The values of *, \$ and f, under various temperatures, are invited in Fig. 1. These values and their temperature derivatives at . ** West Used to calculate the temperature coefficient of electrostriction. The jesuit of numerical calculation by Eq. (3) is shown in Fig. 2 for modified lead since niobate, as well as for modified barium titanate. For modified lead zinc niobate, the temperature coefficient shows a maximum value at 0.8 x 10 $^{\circ}$ V/m. and decreases to below 1.0 %/ $^{\circ}$ C at 1.6 x 10 6 V/m.

5. CONCLUSION

The temperature dependence of electrostriction under a high electric field was investigated for modified lead zinc niobate in a multilayer configuration. The temperature coefficient of electrostriction was estimated to be less than 1.2 %/°C for modified lead zinc niobate. It became clear that its utilization under a high electric field is favorable for temperature stability of electrostriction.

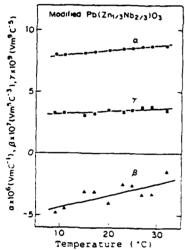
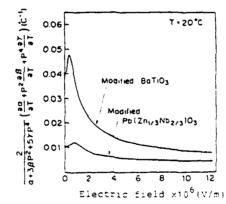


Fig. 1. Temperature dependence of α , β and γ in $E = \alpha P + \beta P^3 + \gamma P^5$.



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Fig. 2. Calculated curves for $\frac{2}{3+3JP^{2}+5TP^{2}}\left(\frac{3\sigma}{3T}-p^{2}\frac{3J}{5T}+p^{2}\frac{3J}{5T}\right)$ as function of electric field.

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PREPARATION AND CHARACTERISTICS OF NEW MONOMORPH ACTUATOR

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ABSTRACT: Bending phenomenon was newly observed in a single ceramic plate of BaTiO $_3$ which was doped by small amount of ${\rm SiO}_2$ and ${\rm Al}_2{\rm O}_3$ or ${\rm Nb}_2{\rm C}_5$. The bending mode may occur by the presence of potential barrier between silver electrode and ceramic semiconductor, as a result of inhomogeneous distribution of an electric field and also by inhomogeneous polarization in oxidized surface layer.

1. INTRODUCTION

In place of usual electromagnetic drive actuator, the piezoelectric ceramic actuator is preferable to control a position for precision machining tools or optical instruments and relays, etc. There are three types of ceramic actuator, that is, multilayer, bimorph, unimorph types. First of them expands along the longtitudinal direction and others have bending mode. In present study, it was found that the ceramic single plate of $BaTiO_3$ which was doped by small amount of SiO_2 and Al_2O_3 or Nb_2O_5 showed the bending effect by applying external field, similar with bimorph—or unimorph—type elements. It was hereafter named "monomorph". In order to clarify the bending phenomenon, a boundary effect between metal electrodes and ceramics and a role of oxidized insulate layer were investigated.

2. EXPERIMENTAL

After BaTiO $_3$ was ball-milled with 5mol\$SiO $_2$ and 2-5 mol\$Al $_2$ O $_3$, the powder was rubber-pressed to compacts. Sintering was preformed at 1250 °C for various periods, 1 to 15 hrs, in air. BaTiO $_3$ doped by Nb $_2$ O $_5$ (0.1 to 1 at%) was also prepared in the similar procedure above-mentioned. Metal electrocodes such as Ag, Au, Ga-In were used to check the electrode effect. Bending effect was measured by both contact method using potentiometer and non-contact sensor method. The sample size measured was 40 mm length, 15 mm width, and 0.5 mm thickness. The measurement was procedured at the position of 28 mm far from the fixed end.

3. RESULTS AND DISSCUSION

A magnitude of bending was strongly influenced by sintering temperature and sintering periods. Most remarkable bending effect was observed in the SiO_2 (5 mole %) and $\mathrm{Al}_2\mathrm{O}_3$ (2 mole %) doped BaTiO_3 ceramics which were sintered for prolonged times such as 10 hrs (Fig 1). In the sample which was sintered for prolonged time, the electric resistivity was relatively low, that is, $\mathrm{10}^{\circ}$ ohm.cm and gathering of impurity phase was observed by SEM and XMA. Theremore, the bending effect was also strongly dependent on the metal electrodes. Fig.2 shows electrode dependence. It is apparent that the sample attached by silver electrode on either one side or both side produces the remarkable bending

effect, therefore, bending effect may occur by the perential partier retween semiconductive ceramics and silver electrode as a result of electric field concentration near their contact boundary.

On the other hand, it is well known that the Nt-doped BaTiO $_3$ shows semiconductive property, of which electric resistivity is 10^3 - 10^4 chm.cm. It was too low resistivity toapply high voltage. Therefore, the surface of the sample was oxidized by electrolysis. Fig.3 shows eletrical resistivity change as a function of distance from the oxidized surface. The resistivity was very high (10^{10} ohm.cm) near the oxidized surface and then decreased to 10^6 ohm.cm inside of the ceramic plate, the sample thus obtained showed large bending effect, regardless various electrodes (Fig.4). The electrostrictive behavior was much diffrent from the one in the $\rm SiO_2$ - $\rm Al_2O_3$ deped BaTiO $_3$ system. This experimental fact suggests that in homogeneous distribution of polarization in oxidized surface layer may play an important role. Although similar phenomenon has been found in poly vinylidene fluoride films 1 , it has never been observed in ceramic single plate.

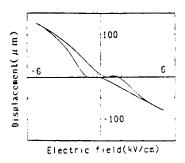
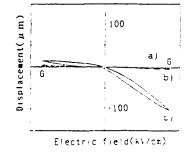


Fig.1. Displacement versus applied electric field for ${\rm SiO_2-Al_2O_3}$ doped ${\rm BaTiO_3}$.



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Fig. 2. Effect of electrode to displacement, u!Ga-In,Ga-Inb)Au,Au, o)Ag,Ga-In

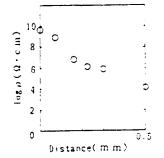


Fig. 3. Pesistivity change as a function of the distance from the surface.

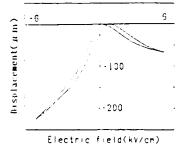


Fig.4. Displacement versus applied electric field for the No-doped ${\rm Ball} \, {\rm G}_3$.

PEFERENCE

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ACKOWLEGMENT

The authors very thank to Prof.K. Uchino at Sophia University for the kindly drection and the fruitful dissousion.

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LASER PATTERNING OF POLYMERS FOR ELECTRONIC PACKAGING

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Polymeric materials have desirable features as a packaging medium for VLSI, multichip circuitry, and as an interconnect substrate. They are inexpensive, can be formed in any desired shape, can withstand required solder temperatures, have excellent dielectric strength and, most importantly, have a very low dielectric constant, thus reducing capacitance coupling between metallization stripes. This capacitance often determines the ultimate speed or frequency limitation of packaged devices.

For hybrid wafer-scale integration, a major concern is the interconnection layout. Many chips are mounted on a substrate and a complex interconnect scheme is required to contact different metal layers to each other and to other chips. Recently, laser-activated chemistry has been shown to be a viable method to fabricate metal lines on various substrates. The production of metal lines by laser-induced deposition techniques offers several advantages over other thin-film deposition processes. The laser process is noncontact, maskless, low temperature, selective, and is relatively simple and economical. A difficulty often encountered in the use of laser-fabricated metallizations in interconnect technology is, however, the relatively high resistivity of the laser-deposited metal, usually due to hydrocarbon contamination. An approach we have adopted to solve this problem will be described. High-conductivity, thick (~5 µm) metallization compatible with chip interconnect process requirements is feasible.

Excimer laser photoetching of polymers has been shown to be a convenient, fast, selective method of producing fine patterns or holes in polymeric materials. Selective etching of polymeric materials is important for discretionary rerouting of interconnects as well as for opening vias in barrier-layer coatings. For practical applications, laser photoetching must be fast, efficient, and not harmful to underlying circuitry. This includes metal bonding pads, silicon chips, and various metal interconnects. Thus, the maximum fluence available for etching polymeric layers must be safely below a level which causes damage to other components.

The effect of laser fluence on etch rates is shown in Fig. 1 for poly(methyl methacrylate). This well-studied polymer shows the general trend found for most polymeric materials. Below about 50 mJ cm², little or no photoablation occurs. This phenomenon requires that a critical number of chemical bonds be broken per unit volume and/or that a critical temperature be reached for significant etching to occur. The absolute value of the absorption coefficient, α , defines the depth within which most of the incident photons are absorbed. One might speculate that if α is low and the absorbed energy per unit volume is small, little or no etching would occur. On the other hand, if α is extremely high, the photons do not penetrate beyond the initial surface layer and the etch rate would also be low. Therefore, one would predict that at each fluence level above threshold, a maximum etch rate would exist for absorption coefficients between the above extremes. This is experimentally verified in Fig. 2. In this work, polymer blends of poly(α -methyl)styrene and poly(methyl methacrylate) and copolymer blends (styrene allyl a cohol copolymer in butylvinyl ether maleic anhydride copolymer) were prepared in order to vary the absorption coefficient over several orders of magnitude. A constant fluence of 200 mJ/cm² was used in one study and 100 mJ/cm² in the other. In both cases a maximum in etch rate was found when α was adjusted to about 10^4 cm⁻¹.

Optimization of the polymer etch rate by tailoring α will thus allow the fastest rate polymer via hole drilling without damage to the underlying circuit components.

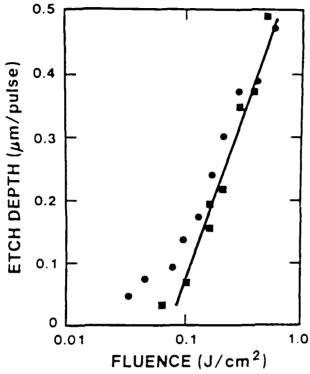


Fig. 1. Photociching rate of PMMA at 193 nm (# this work)

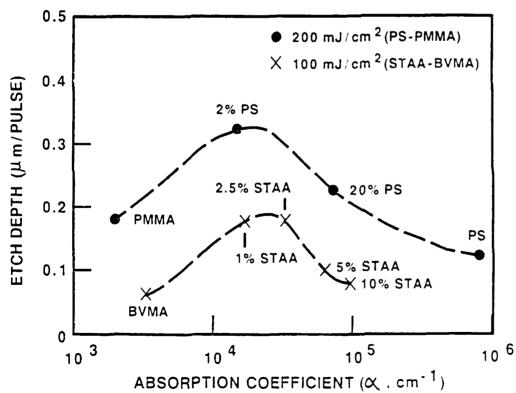


Fig. 2. Effect of absorption on photoetching rate (193 nm. 12 nsec pulse)

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CHARACTERIZATION OF THE ROLE OF EXCESS MAGNESIUM OXIDE AND LEAD OXIDE IN LEAD MAGNESIUM NIOBATE

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ABSTRACT: $Pb(M_{S_1/3}N_{b_2/3})O_3$ (referred to as PMN) is the most studied of the diffuse phase transition or relaxor ferroelectrics. The ceramic can be prepared with peak permittivities of 25,000 (100 Hz) which suggests very "clean" or uninhibiting grain boundaries when considering electric flux continuity. This suggests that the grain boundary is either very thin or is composed of a high dielectric constant material. Alternately, the ceramic exhibits almost 100% intragranular fracture and moderate-to-low fracture strength suggesting that the PMN grain boundaries are very weak. This paper partially explores the chemistry and characteristics of these grain boundaries.

Near-phase pure PMN with MgO and PbO additives was produced by the method of Swartz and Shrout by sintering at 1200° C. The material was characterized by SEM, x-ray diffraction, SIMS and dielectric measurements.

The microstructural studies supported the recent TEM study of Goo. Batching with excess PbO developed a continuous PbO rich phase in triple point regions of the grain boundary. Batching with MgO developed isolated inclusions of MgO rich material in the grain boundary and in the grains. Both were essentially absent in unaltered PMN. SIMS studies suggested that all modifications develop a microstructure having an increased ratio of lead in the first few hundred angstroms of the grain boundary. Quantitative analysis of the lead excess content is prevented by preferential sputtering of lead.

Dielectric measurements indicated that the highest MgO excess composition also had the highest peak dielectric constant, which was 25,000 at 100 Hz. Analysis using inverse dielectric constant versus temperature suggests that doubling the excess lead content doubles the thickness of the grain boundary. This was graphically demonstrated by parallel shifts in the high temperature curves. Excess MgO, however, gave a considerably different response. The 1/K equals zero intercept remained nearly constant while the slope (1K over temperature squared) decreased with increasing MgO. This seems to indicate that while MgO appears to have a very low solubility in PMN, the presence of discrete MgO particles affects the low frequency contributions to the dielectric constant. This interaction suggests that the MgO inclusions could decrease the diffuseness of the phase transition.

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TRIVALENT IMPURITIES IN Batio;

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ABSTRACT: The effect of small additions of trivalent metallic impurities on the electrical conductivity of BaTiO₃ has been studied for samples having an excess of either BaO or TiO₂. The properties change gradually with the ionic radius of the impurities, indicating that those of intermediate size occupy both Ba and Ti sites in varying amounts that depend on the Ba/Ti ratio.

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1. INTRODUCTION

Based on the compatibility of ionic charge, impurity cations having a charge greater than 4 are expected to occupy only the Ti sites in BaTiO₃, while those having a charge less than 2 should occupy only the Ba sites. Trivalent impurities are a special case in that their charge is intermediate to those of Ba⁺² and Ti⁺⁴, and their site preference is expected to depend strongly on their ionic radii. The trivalent impurities Al, Sc, Y, La, Nd, Sm, Dy, Er, and Yb have been added to BaTiO₃ having an excess of either BaO or TiO₂, and the equilibrium conductivity, measured as a function of the oxygen partial pressure at 1000°C, has been used as an indication of the site occupation.

2. EXPERIMENTAL

The samples were prepared by the liquid-mix process $^{1,2)}$. 1200 atomic ppm of each impurity was added to solutions having Ba/Ti ratios of 0.99, 1.00, and 1.01. The electrical conductivity was measured on sintered bars by a standard dc, 4-point technique $^{2)}$.

3. RESULTS

Trivalent impurities substituted for Ba behave as donors, while those substituted for Ti behave as acceptors. The two situations lead to distinctly different dependences of the equilibrium conductivity on the oxygen partial pressure. By comparison of the experimental results with theoretical curves calculated for occupation of both sites in different ratios, it is possible to obtain quantitative information on the amount of impurity on each site.

The smallest impurities, Al, Sc, and Yb, show strong acceptor-doped behavior, indicating a pronounced preference for the Ti site. The largest impurities, La and Nd, appear to occupy only the Ba sites. Between these sizes, there is a steady shift from Ba sites to Ti sites with decreasing ionic radius of the impurity. The Ba/Ti ratio has the greatest effect on Y and Er, which give predominantly donor behavior in the presence of excess Ti, and acceptor behavior in the presence of excess Ba. These two impurities, with nearly identical ionic radii, can occupy either site with almost equal ease, and represent the transitional cases.

4. CONCLUSIONS

The experimental results are in general agreement with theoretical calculations of site preferences 3), except that there is less tendency than predicted for equal occupation of both sites to achieve self-compensation. The two transitional impurities, Y and Er, can give either semiconducting or insulating \mathtt{BaTiO}_3 at room temperature, depending on very small differences in the $\mathtt{Ba/Ti}$ ratio.

5. ACKNOWLEDGEMENT

This work was supported by the Division of Materials Research of the National Science Foundation.

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LINE-FOCUS-BEAM ACOUSTIC MICROSCOPE SYSTEM FOR NONDESTRUCTIVE EVALUATION OF ACOUSTIC INHOMOGENEITY ON PZT WAFERS FOR SAW DEVICES

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ABSTRACT: The line-focus-beam acoustic microscope system has been developed which can inspect elastic properties of materials over an area of 55mm X 55mm with a measurement accuracy better than ±0.03% in velocity measurements. The evaluation of acoustic inhomogeneity on PZT ceramic wafers for SAW devices has been made successfully with this system. Large variations in SAW velocity have been detected on a wafer sample and also among wafers.

1. INTRODUCTION

Recently, the novel material characterization method has been established by means of a line-focus-beam acoustic microscope 1). The method can be used to determine acoustic properties of materials quantitatively, viz., velocity and attenuation of leaky surface acoustic waves (SAWs) propagating along the boundary between a sample and a reference liquid of distilled water. The measurements are made nondestructively through the V(z) curve analysis. The accuracy is so high that the system can be employed to detect a small change of elastic properties of materials.

In this paper, the construction and reliability of the system of line-focus-beam acoustic microscope is described that can measure the two-dimensional velocity variation on a material surface. Experiments are demonstrated for PZT ceramics, using an acoustic line-focus-beam sapphire lens at 225 MHz. The acoustic inhomogeneity on wafers detected by this system is discussed being compared with the variation of SAW device characteristics.

2. SYSTEM

Fig. 1 shows a block diagram of the system, which can be applied to acoustic inhomogeneity mapping on materials. The system consists of four main parts: 1) an acoustic probe, 2) a pulse mode measurement system of transmitting and receiving electrical signals, 3) a mechanical system of alignment and movement to record V(z) curves, and 4) a computer for controlling the system and for processing the recorded curves. V(z) curves are recorded into a wave-memorizer synchronized with the translation of sample driven by a stepping-motor, and then they are processed by a computer. The temperature of water and the acoustic frequency are also measured and recorded. Using a set of these data (V(z) curves, temperature, and frequency), propagation properties of leaky SAWs are precisely determined.

In order to check the reliability of the measurement, the system is applied to measure the velocity for a (111)GGG wafer, which is a typical single crystal without defects. It is confirmed that the relative velocity resolution is petter than ± 0.018 and the system error for two-dimensional scanning is within ± 0.038 over an area of 55mm X 55mm.

7,7

3. EXPERIMENTS

Experiments have been made for several P2T wafers of two-inch diameter with a grain size of 1-2 µm practically used in manufacturing SAW devices such as TV-VIF filters. For the filters, the variation of SAW velocity on wafers should be within 10.1%.

Fig. 2 is a typical V(z) curve for a PZT wafer. By analyzing this curve according to the measurement principle, the velocity of leaky SAW is determined to be 2432 m/s. The Velocity distribution on the wafer has been measured at the center of each segmented piece with 5mm X 5mm square as shown in Fig. 3. The remarkable inhomogeneity is observed. The velocities hear the center are slower than those for the periphery. The two-dimensional average velocity for the wafer is 2436 m/s with maximum difference of 0.7%.

The acoustic inhomogeneity will be discussed in detail as compared with the characteristics of SAW filters associated with device location on the wafer.

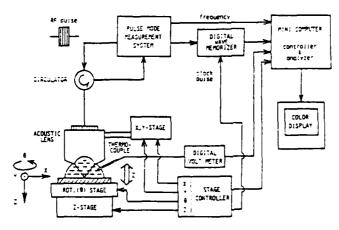


Fig. 1. Block diagram of the line-focus-beam acoustic microscope system.

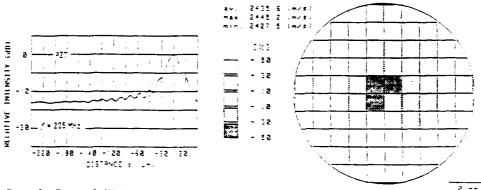


Fig. 2. Typical V(z) curve measured for P2T ceramic wafer.

Fig. 3. Distribution of leaky SAW velocity on PST denamic wafer.

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W-20

ELECTRICAL PROFESTIES OF Obj. 32 TE (ACEL OTERM.) OA TOT

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ABSTRACT: Electrical properties of $\{5r,5a\}$ Tilly based becamic variation were investigated. Surge absorption characteristics of samples of which the basic sericonductive decamics were fired in two reducing atmosphere were examined in relation to the resistivities of the based semiconductive decamics, the impedance of the decamic variators and so on. The resistivity was 3.14 Mom at sample(A), or 0.09Ω cm at sample(B), respectively. The resistivity was decreasing with increasing of H2 concentration in the firing process. Sample(B) indicated an excellent surge absorption characteristics in the region of high impulse surge voltages compared with that of Dample(A). The depressed voltage was known at sample(B), or javo at sample(A), respectively, when a high impulse surge of $5000V(8/20\mu\text{s})$ was supplied to samples. The difference of this depressed voltage is originated from the resistance of the semiconductive grains.

1. INTRODUCTION

Microstructures and some electrical properties of SrTiC3 or (Sr,Ca)TiO3 based ceramic varistors were reported by our previous papers¹-C). It is well known that (Sr,Ca)TiO3 based ceramic varistors have a high apparent permittivity and a high surge absorption capability. However, The varistor characteristics of these ceramic varistors are unknown in the region of a high current surge or a high voltage surge. In this work, we present the varister characteristics in the region of a high impulse surge in the relation to the resistivity of the cased semiconductive ceramics, the impedance at the resonant frequency of the varistors and so on.

2. EXFERIMENTAL

The startig materials used in this study were high purity materials of SrCCs, T102, JaCO3, Nb2O5 and small mount of additives. The basic components were weighed, respectively and the powder mixtures were ball-milled for 15 nours. The mixed powders, with an approupriate organic binder, were pressed into tablets under a pressure of 108Pa. After burning the binder, the tablets were fired at a temperature of 1980°C-1420°C in 98502-2982 or POS02-10882 apposphere, respectively. In order to make BL structures, a paste including MagD was printed on the surface of semiconductive peramics. The printed specimen were heat treated at 1150f0-1250f0 in air for the grain coundary diffusion of the printed materials. In-Ja alloy were attached to the surfaces of semiconflictive deramics for the measurement of the resistivities. Silver electrones were fired on the surfaces of the beramics after the grain boundary diffusion. I. + Lateritance were measured using a depacttance bridge. The impedance at various frequency were reasured using an impedance analyzer/MHF: model=4191 . The current was resoured by an archere beter. A stanzard impulse wave of 8,20us in width was used to examine the curry paparilities of 'Sr.Ca, TiOg based deramic variators.

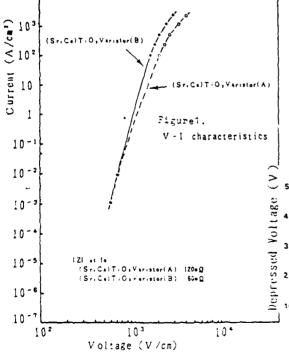
3. RESULTS AND DISCUSSIONS

ilectrical projections of the resulting taken variating and the lastic embeddance tive deramics were measured. The typical values are chewn in the term 1. The taken semiconfluctive deramics of lamples were fired at 1.1172 in $-70(\pm 0.0)$ attroop event sample(A), or in $-0.00(\pm 1.00)$ attroophere at cample(B), respectively. As can be seen in table-1, the resistivity of the basic semiconductive event in war. The impedance of 1.107cm at sample(B), respectively. The grain cize of the based deramics fired at 1.110.0 was from in average and was almost the same each other. The impedance at the resonant frequency of samples was 1.00 mM at sample(A) and tom(A) tample(B) respectively. These results seem to indicate that the recipitivity of the basic confoundative peramic grains of sample(B) is evidently lower than that of sample(A). The W of both samples were almost the came values.

Figure-1 shows a 1-7 caracteristics of cample/4 and (R). The 1-7 curve of both samples is almost the same line in the region below 100mA. However, 1-7 curve of sample(B) showed a more sharp uprised line compared with that of sample (A). Surge absorption capabilities of sample(A) and sample(E) were examined respectively when various high impulse voltage (8/20µs in width) were supplied to the samples. The results are shown in figure-2. When the impulse voltage of 5000V was supplied to samples, the depressed voltage was 340V at sample(A) or 280V at sample(B), respectively. The surge absorption capability of sample(B) was higher at a supplied surge voltage above 1000V than that of sample(A). As a consequent, this difference of surge absorption capabilities between sample(A) and sample(B) is originated from the resistance of the semiconductive ceramic grains.

Sample No.	٥.	Capitance	iZol	@ VI=A-V10=A	VIAA
٨	0,14(Ω-cs)	19700(pF)	120(•Ω)	17.2	80.0(V)
â	0.09(Ω-cm)	20100(pf)	65(±Ω)	17.5]81.5(V)

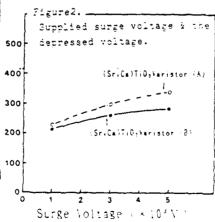
table-1. Electrical Properties of (Sr.Ca)TiO, Variators, (A)or(B),



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4. REFERENCE

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W-21

Defect Structure and Hectrical Epsperty of catomped carrier litarate

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ALSTRACT: A new semiconducting mechanism of La-doped barium titanate on firing was proposed. The relation between the degree of dissolution of La into host and resistivity—as a function of firing temperature in the doped materials was examined to check reliability of the reported semiconducting mechanism in which electrons forms directly to compensate plus charge of $\text{La}_{\text{Ra}}^{-1}$. The variation of resistivity with Po_2 at clevated temperatures was successfully interpreted in terms of the new mechanism.

1. INTRODUCTION

One often add intentionally aliovalent impurities into ceramics for controlling their sinterability and properties through variation of levels of point defects, electrons and holes. One of the rost important defect equilibria in these doped materials is on a controlling valency mechanism. We have proposed a new semiconducting mechanism of rare-earth-doped barrum titanate on firing at elevated temperatures? Which is different from the interpretation in terms of such a controlling valency mechanism. The present study relates to the interpretation of the variation in resistivity as a function of Po₂ along with the new mechanism.

J.EXPERIMENTS

La-doped barium titanate of composition, "Ba $_{0..9}$ La $_{0..1}$ TiO $_{3..05}$ " was prepared by firing at pemperatures 1050 1380 °C and then quenching down to room temperature. The electrical conductivity, ∞ and lattice constant as a function of firing temperature were determined. The observed and calculated densities on a basis of two different ideas were determined as a function of Po $_2$ at the time of firing at 1200 °C in an effort to decide the defect structure of the doped materials.

3.RESULTS and DISCUSSION

Fig.1 shows lattice constant of undoped and doped barium titanates which were prepared by quenching from the indicated temperatures down to R.T. This indicates La dissolution into host to occur completely at least at 1050 °C. Fig.2 shows at R.T. as a function of firing temperature for these quenched specimens. This shows that the semiconduction was achieved on firing at temperatures above $\approx\!1250$ °C. These two data may rule out the reported semiconducting mechanism of La-doped materials in which electrons forms directly to compensate plus charge arising from $La_{\rm Ra}^{-1}$.

It is widely known that ∞ in the doped n-type semiconductor decreases with increasing Po, at elevated temperatures. This behavior has been

interpreted in terms of tendency toward "electronic compensation" in lower Foliand Tionic compensation in higher Police. According to our model, on the other hand, thus behavior in the doped material can be explained by further progress. Of thermal formation of oxygen vacancies plus electrons with decreasing ross in which the levels of cation vacancies formed for

compensating plus charge ,La Ba remain constant over a range of Po, considered. The appropriate way to decide the true Jefect structure controlling the variation in a-may be to determine densities directly to compare with densities calculated on a basis of the forgoing two different ideas. The density measurements were carried out with specimens prepared by firing at 1200 °C at various Po, and then quenching down to room temperature with maintaining the Fo_2 . The results show in Fig. 3, indicating our model to be plausible.

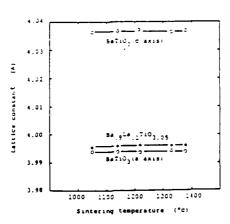
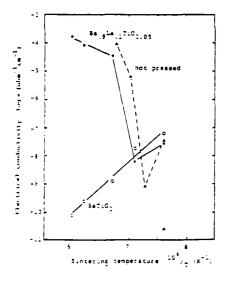


Fig. 1. Lattice constant as a function of firing temperature for ${\rm BaTiO_3}$ and doped specimen of composition ${\rm Ba_0}$ ${\rm _0La_0}$ ${\rm_1TiO_3}$ ${\rm_{0S}}$ ", quenched from the indicated temperatures:



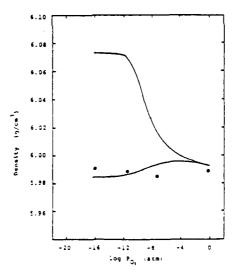


Fig. 2. Electrical conductivity as a function of firing temperature for BaTiO, and doped specimens of composition Ba old TiO, and quenched from the indicated temperatures.

Fig.3. Observed(*) and calculated densities (—) as a function of Po, at the time of firing two different calculated densities relate to a model based on transition from 'electronic compensation" to 'ionic compensation"(upper line) and our model (lower line).

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W-22

DETERMINATION OF A COMPOSITIONAL FLUCTUATION IN PERCUSKITE TERNAPY SYSTEMS

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ABSTRACT: It was developed to determine a region of a compositional fluctuation in perovskite ternary solid solution systems, $Pb(M_{\rm I},M_{\rm II})O_3$ -PbZrO₂-PbTrO₂. The compositional fluctuation in the ternary systems extends two-dimensionally. Such a compositional fluctuation was determined from isoplethic curves of lattice spacings and fluctuations of lattice spacings in the ternary system.

1. INTRODUCTION

The authors have reported methods to determine a compositional fluctuation in perovskite solid solutions of types of $A(B_{\underline{I}},B_{\underline{I}\underline{I}})O_{\underline{J}}^{(1)}$, $(A_{\underline{I}},A_{\underline{I}\underline{I}})BO_{\underline{J}}^{(2)}$, and $(A_{\underline{I}},A_{\underline{I}\underline{I}})(B_{\underline{I}},B_{\underline{I}\underline{I}})O_{\underline{J}}^{(3)}$. It was revealed that solid solutions tend to have compositional fluctuations. If a solid solution has a compositional fluctuation fluctuation, many properties are affected. The compositional fluctuations can have merit in some cases and demerit in other cases. Anyway it is important to grasp the compositional fluctuation.

Ternary solid solutions of $Pb(M_I,M_{II})O_3$ - $PbZrO_3$ - $PbTiO_3$ systems are useful because the morphotropic phase boundary of them, whose compositions have excellent electrical properties, exists along a line in a ternary phase diagram. Properties of solid solutions are largely varied by a way how the compositional fluctuation extends. Thus far there were no methods to determine the compositional fluctuation in the ternary systems. In this study, a method was developed to estimate such a two-dimensional region of the compositional fluctuation.

2. THEORY

A fluctuation of lattice spacing can be determined by widths of X-ray diffraction (XRD) peak. For two-component systems, the fluctuation of lattice spacing corresponds directly to the compositional fluctuation as shown in Fig. 1. On the contrary, for the ternary systems the compositional fluctuation range can not be determined completely from the fluctuation of a lattice spacing. A schematic diagram of isopleth of a certain lattice plane is shown in Fig. 2. Now we consider that the lattice fluctuation range is estimated to be from d_1 to d_2 by the XRD measurement. Such a fluctuation of the lattice spacing can occur in either a case of (a) or (b) shown in Fig. 2. Only information which the measured fluctuation range of lattice spacing means is that the compositional fluctuation occurs within the area indicated by shaded region in this figure.

If the possible compositional fluctuation region expected from another plane is as indicated in Fig. 3, a possible compositional fluctuation range must be restricted within the common shaded area in Fig. 2 and Fig. 3. Furthermore if fluctuations of various lattice planes are measured, the common area will be more restricted and it will approach the true compositional fluctuation area.

3. EXPERIMENTAL

Pb0, Mg0, Nb205, 2r02, and Ti02 were blended in lestred ratios and mixel thoroughly in an agate mortar with a pestle. The mixed oxides were pressed into powder compacts and fixed at 1200°C for 1h, resulting in solid solutions of $Pb(Mg_{1/3}Ta_{2/3})0_3-PbTi0_3$ system (PMTZT). Lattice constants of materials having tetragonal symmetry were measured by XRD. The value of 3, which is a net width of XRD peak due to a sample itself, was calculated by subtracting the effect of doublet of characteristic X-ray and the resolution of the apparatus from the measured value, using Si as a standard.

4. RASULTS AND DISCUSSION

The relations between lattice constants and compositions are shown in Fig. 4 and 5, using isoplethic curves. Lattice spacings of (111), (102), and (103) were calculated from the lattice constants, and equal lattice spacing lines were drawn in the ternary system diagrams.

Fluctuation ranges of lattice spacing of (001), (100), (111), (102), and (103) of the PMTZT (Pb{(Mg $_{1/3}$ Ta $_{2/3}$) $_{0.2}$ (Zr $_{0.3}$ Ti $_{0.7}$) $_{0.8}$ [0 $_3$) were determined from the plots of 8cos0 and sin0. Using these values and the diagrams of equal lattice spacing lines, the limits of the compositional fluctuation were estimated and are shown in Fig. 6. The compositional fluctuation region is concluded to be the area illustrated by solid line, namely, ellipse.

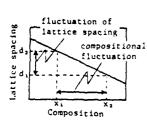


Fig.1 Relation between fluctuation of lattice spaing and that of composition

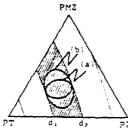
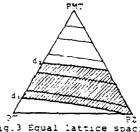


Fig.2 Equal lattice spacing lines of a certain lattice plane



■ できないのでは、「これをなるないのでは、「これできないない。」

Fig.3 Equal lattice spacing lines of a lattice plane different from Fig.2

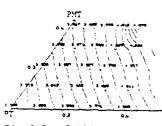


Fig.4 Isoplethic curves of a-spacing

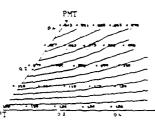


Fig. 5 Isoplethic curves of c-spacing

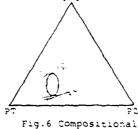


fig.6 Compositional fluctuation region estimated for PMTST (1200°C, lh.)

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W-23

PROPERTIES OF THE ALL CERAMICS

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ABSTRACT: Aluminium nitride ceramics were made by a doctor blade method using Y_2O_3 as a sintering additive. Some kinds of compounds which were made in the Y_2O_3 - Al_2O_3 system were observed as extra phases in the AlN ceramics. And such compound tend to correspond respectively to the thermal conductivity of the AlN ceramics. In the process of manufacturing AlN ceramics, the conditions to realize small molar fraction of Al_2O_3/Y_2O_3 are desirable for achieving the higher thermal conductivity.

1. INTRODUCTION

Yittrium oxide is well known as one of the most effective sintering additives for AlN ceramics. It reacts to ${\rm Al}_2{\rm O}_3$ impurity in AlN powder and its reactant melts during the temperature increase. This melting accelarates the AlN sintering process, and this melted compounds confined only at triple points of AlN grains. This paper studies the composition of reactants and its correlation to the thermal conductivity of the AlN ceramics.

2. EXPERIMENTATION

2.1. Materials

Aluminium nitride powder was mixed with $\rm Y_2O_3$ using an organic binder. After removing the binder from the ceramic green sheets, the sintering was made at 1700- 1800°C in the nitrogen atmosphere.

2.2. Measurements

Thermal conductivity was measured by the laser flash method using IR sensor at around 25°C. Samples were columnar about 10mm in diameter and 3mm thick.

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3. RESULTS AND DISCUSSION

Thermal conductivity of AlN was decided dominantly by the oxygen impurity in raw material powder (Fig. 1) and manufacturing process. The X-ray diffraction revealed there were various kinds of compounds in the sinteredbody, such as AlON, $3Y_2O_3$. $5Al_2O_3$, Y_2O_3 . Al_2O_3 and $2Y_2O_3$. Al_2O_3 (table 1). Increasing the thermal conductivity, decreasing the molar fraction of Al_2O_3/Y_2O_3 of the compounds. The oxygen at the grain boundaries which reduces the thermal conductivity is the remainder from impurity, which are left during sintering process.

From Fig. 1 and table 1, we think the smaller molar fraction of ${\rm Al}_2{\rm O}_3/{\rm Y}_2{\rm O}_3$ is, the smaller is the residual oxygen at the grain boundaries. Therefore, this molar fraction has the probability to be a good index to judge whether the manufacturing process is appropriate or not.

Tuble 2 shows the properties of the AIN ceramics in comparison with other materials. Thermal conductivity is 170 w/m.K, and thermal expansion coefficient is 4.8 ppm/C, which is close to the value of Silicon.

BeO and SiC have higher thermal conductivity than AIN. But BeO is toxic, and SiC needs hot pressing for sintering.

As an example of its applications, AlN is very suitable for nigh power devices.

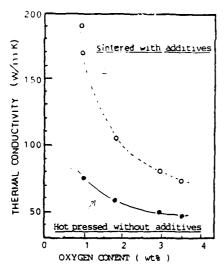


Fig. 1 Relation between oxygen content of AlN raw powder and thermal conductivity

Table 1 Compounds in the AlN ceramics which have various thermal .conductivit@\$

K-value	Compounds
110 W/m.K	YAG > Alon
140	YAG
170	YAL > YAG
190	YAM ~ YAL > YAG
235	Y ₂ O ₃ ≯ YAM

YAG: 3Y₂O₃.5Al₂O₃ YAL: Y₂O₃.Al₂O₃ YAM: 2Y₂O₃.Al₂O₃

Table 2 Properties of the AlN ceramics

Items	Unit	AlN	A1203	BeO	S_C
Thermal conductivity	W/m.K (r.t.)	170	20	250	270
Electrical resistivity	Ω.cm (r.t.)	10 ¹⁴	1014	1014	10 ¹³
Dielectric constant	E/EJ (1MHz)	8.8	8.8	6.5	40
Dielectric loss	×10 ⁴ (1MHz)	5-10	3	5	500
Dielectric strength	kV/cm (r.t.)	150	100	100	0.7
Thermal expansion coefficient	10 ⁶ / C	4.5	7.3	8	3.7
Density	(R.T. 3400 C)	3.3	3.9	2.9	3.2
Young's modulus	10 ⁻⁴ kg/mm ²	2.8	3.7	3.2	4.8
Flexural strength	kg/mm ²	40-50	24-26	17-23	45

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The Third U. S.: Japan Seminar on Dielectric and Piezoelectric Ceramics

Posters

Co-chairman T. Yamaguchi, Keio University
Co-chairman S. W. Freiman, National Bureau of Standards

Chairman of Program Committee, H. Banno, NGK Spark Plug Co. Chairman of Financial Committee, K. Wakino, Murata MFG.Co. Chairman of Tour Committee, N. Ichinose, Weseda University Chairman of Executive Committee, A. Okamoto, TDK Electronics Secretary, T. Kimura, Keio University

November 9-12, 1986 YKK COnference Hall Toyama, Japan

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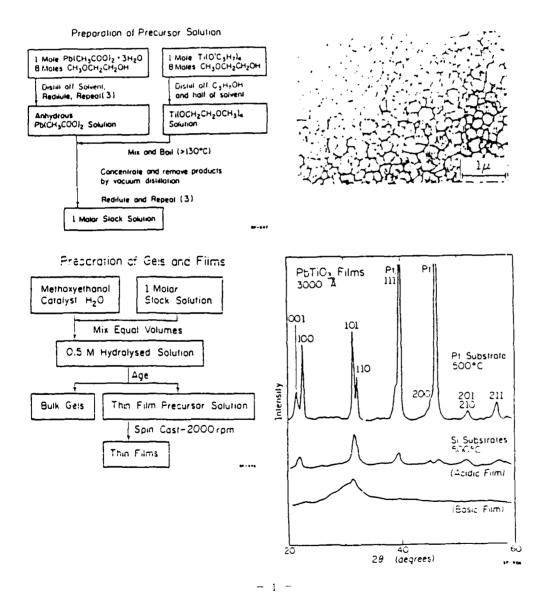
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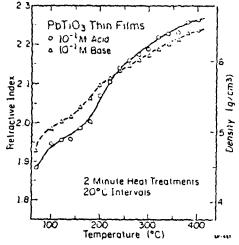
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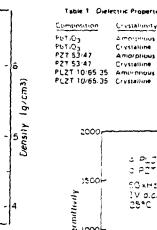
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INTRODUCTION: An upset technology is in the making for the fabrication of dielectric thin-films by polymeric sol-gel processing. This novel processing route avoids powder (and attendent problems), and produces films of exceptional quality at relatively low temperatures. The present study reports on recent measurements on ferroelectric and dielectric properties.







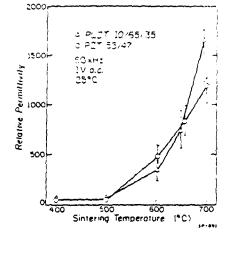


Table 1 Dielectric Properties of Sol Gel Derived Thin-Films Fermittivity

78 - 43 155 - 185

Crystalianity

Dissipation Factor

0.003 = 0.030

35 D DD5 - 0 010 300 - 1200 D 020 - 0 010 25 D 055 - 0 010 390 - 1700 D 020 - 0 020

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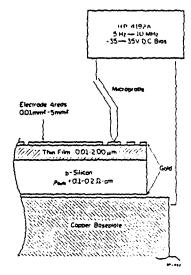
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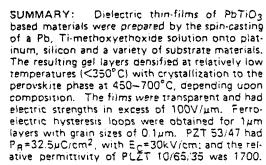
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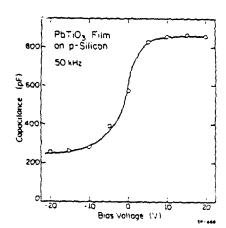
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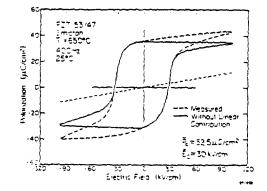
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Metalla - Organic Compounds

Dissaive in Solvent/ Solvent Mixture

Formulation

Adjust Viscosity

ink

Print

Wet Film

Dry 8 Fire

Dielectric Film

Flow chart of HOD process for dielectric films.

PREPARATION AND PROPERTIES OF

FERROELECTRIC FILMS FROM

METALLO-ORGANIC PRECURSORS*

ROBERT W. VEST

PURDUE UNIVERSITY

W. LAFAYETTE, INDIANA

 SUPPORTED BY THE OFFICE OF NAVAL RESEARCH UNDER CONTRACT No. NO0014-83-K-0321

COMPOUND REQUIREMENTS

- 1. THERMALLY DECOMPOSE WITHOUT MELTING OR EVAPORATING TO GIVE THE METAL OR METAL OXIDE PLUS VOLATILE SPECIES
- 2. HIGH METAL CONTENT
- 3. HIGH SOLUBILITY IN COMMON SOLVENTS
- 4. STABLE UNDER AMBIENT CONDITIONS
- 5. COMPATIBLE WITH OTHER COMPOUNDS IN THE FORMULATION
- 6. COST EFFECTIVE TO PRODUCE AND HANDLE

STRINESIS

BONSEL DECOMENSISSES CADA Lambullan 2016

MH 20H - RCDOH ------> PCDCHH4 + H=0

 $\mathsf{MS}_{\underline{A}} \leftarrow \mathsf{aRCOOPH}_{\underline{A}} \leftarrow \cdots \rightarrow \mathsf{MIRCOOT}_{\underline{A}} \leftarrow \mathsf{aMH}_{\underline{A}} \underline{X}$

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8.4	he opec amesc	Bally
Ps	46 006 C+401C	PECHOSIS
Sa.	NE TOE CAMBIE	SPCL
14	7 - 0 1 HTL ME 2 A HO 1 C	146.
Se	2 - g 1 m + t mg + a mp + C	S=Cc-
	1.41mm mt 14mm f	8:180-1-

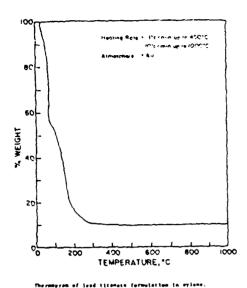
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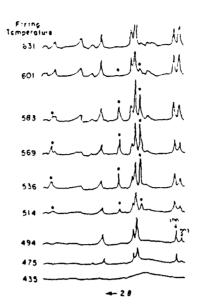
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PTIC;H107=1-2CL4 + HCH15-DDM4 > PTIC3H1042-2-1C)H15:DD14 + mm4CL

- 3 -





2-ray diffraction patterns (with Cut $_{\rm p}^{-1}$ for fffine (1 ν) fixed on Pt fe() at vertous commutatives. The indicated mosts are mot characteristic of twistermal PSTIO,

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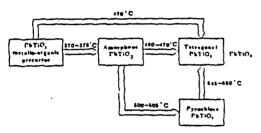
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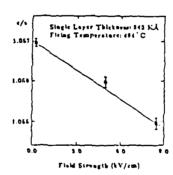
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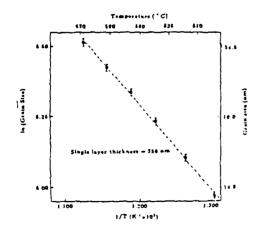
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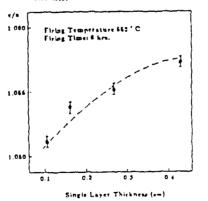




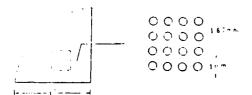
The dependence of c/a on D.C. electrical field strength during firing for the file with 2.42 M in single laver thickness.



The grain aire dependence of Patity likes on thring comparature.



The dependency of c/s on the single laver thickness



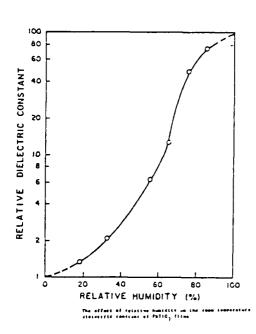
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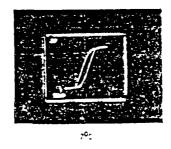


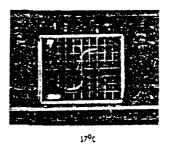
an illustration of planer consistent made by $O(O_{\chi})$ of a contribution of consistent will be consistent to a 2-cm of 2-cm



TEN X30.000 1 cm = 0.3 \times Pb(10 $_3$ film deposited on one layer Pt (>10 cm) conted S1 wafer fired at 500 0 C for 8 hr. in air.

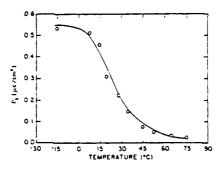




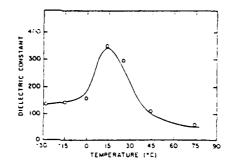


x: 83.0 kV/cm/dlv. y: 0.254 wc/cm²/dlv. f=50 Hz

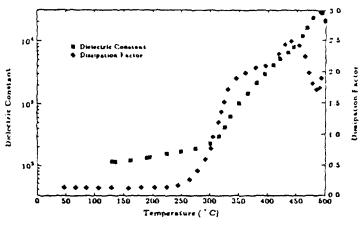
Ferroelectric Hysteresis Loap for $\text{Pb}_{0.37}\text{Sr}_{0.63}\text{Ti}_{03}$ Film of 26 nm Grain Size.



. Temperature dependence of P_g for . Pb $_{9.7}$ Sr $_{0.95}$ Sr $_{0.95}$ Pilm measured at 30 Mz (grain size ~ 26 nm).



Temperature dependence of Dietectric Constant for PE_{0.11}, St_{0.11}, St_{0.11}, TiO₂. From measured of 1 kHz, option size m.26 kms

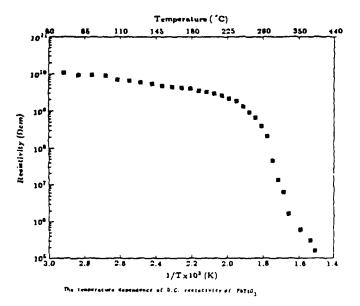


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The temperature demandance of disloctric constant and dissipation factor for a terragonal Phys $\theta_{\rm p}$ file (.8) un thick.



SUMMARY

- 1. Defect free ferroelectric films ($\Rightarrow 1$ um) over 2 cm. X 2 cm. AREA.
- 2. LOW TEMPERATURE PROCESSING (490°-700°C)
- 3. Easy control of composition (e.g., $PB_XSR_{1-x}T10_3$).
- 4. CONTROL OF GRAIN SIZE AND ORIENTATION.
- 5. $PBTIO_3$ FILMS EXHIBIT BULK DIELECTRIC PROPERTIES.
- 6. (PBSR) TiO_3 Films exhibit relaxor behavior.

Fabrication of Gram-Oriented KSr₂Nb₅O₁₅ Ceramics

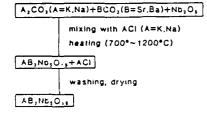
T. Kimura, Y. Ogino and T. Yamaguchi

Keio University

Objectives

- To prepare needle-like powder particles in alkali-alkaline earth niobate systems, AB₂Nb₂O₁₆.
- To study the relation between direction of needle and crystal axis.
- To prepare grain-oriented ceramics by normal sintering.

Powder Preparation



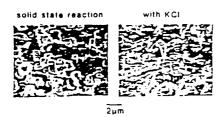


Fig. 1. Effect of molten salt on the particle shape of KSr₂Nb₃O₁₃. Molten KCI is necessary to prepare needle-like particles.

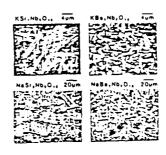


Fig. 2. Particle morphology depends on the chemical apacies of A and 8. Small needle-like particles with large espect ratio are obtained in the system KSs(Nb,O., 1200°C 3 h.

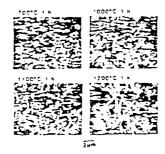
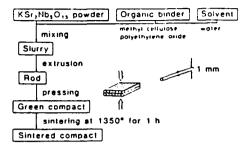


Fig.3. Effect of preparation temperature on the deflice morphology of \$5 \text{NN}_0.0... Equivaled particles to made in the temperature (FCCTC) grow to needle-tike particles above 110010.

Forming and Sintering



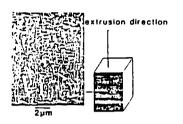
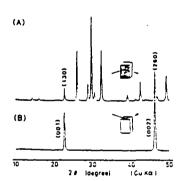
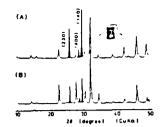


Fig. 4. SEM's of the surface of a green compact, indicating particle alignment.





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Fig. 5. X-ray diffraction patterns of (A) green compact and (B) aquiaxed powder. The intensities of (hk0) lines are higher in the green compact, indicating orientation of crystal axis.

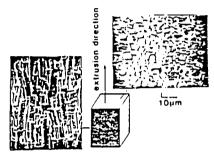


Fig. 6. SEM's of the sintered compact. Grains are rod-shaped and rod axes are aligned parallel to the extrusion direction.

Fig. 7, X-ray diffraction patterns of a sintered compact. The intensities of (hkO) lines increase by sintering (A). Only (001) lines are observed in the plane perpendicular to the extrusion direction (B).

These results indicate that c-axis (polar axis) is parallel to the needle axis.

Conclusions

- 1. Small needle-like particles with large aspect ratio are obtained in the system KSr₂Nb₅O₁₅.
- 2. The needle axis is parallel to c-axis, which is the polar axis.
- Grain-oriented ceramics are obtained by extrusion forming and normal sintering.

. # -

Properties of Sub-micron PaTiOs with Additives
for Low Firing Temperature

Kazunobu Abe, Masashi Aoki, Eiyoshi Fukai and Kazuhisa Hidaka

Research and Development Division, Sakai Chemical Industry Co., Ltd., Sakai, Osaka Japan

We previously reported on the powder properties, sintering properties and electrical properties of Barium

Titanate powder obtained by hydrothermal synthesis. This powder was easily sinterable; its particles are spherical in shape, uniform in size (0.1µm) and sinterable at 1,200°C.

In this study, examined were the sintering and electrical properties of Barium Titanate powder with an additive for low firing temperature. Comparisons were made among three powder production methods, i.e. the hydrothermal synthesis method, the oxalate method and the calcination method, and among various additives for low firing temperature. As a result, it was found that the hydrothermal synthesis method provides the most excellent sintering and electrical properties for Barium Tintanate powder with an additive for low firing temperature. The sample powder with one of the tested additives, in particular, was found to sinter at 1,000°C when added even in a very small amount (0.5 ~1.0 mole%) and therefore maintain an excellent electrical properties. It can be expected that the use of

Barium Titanate produced by the hydrothermal synthesis method and this additive in combination will contribute to the cost reduction for multilayer capacitors because it raises the ratio of Aq content of Pd-Aq alloy used in the internal electrode.

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In addition, it was found that when some additives are used, an unique sintered product maintaining a cubic system is obtained.

1. Introduction

The authors previously suggested that Barium Titanate produced by the hydrothermal synthesis method not only satisfies the requirements of ceramic production, i.e. "fine", "spherical", "uniform", and "highly pure", but also possesses excellent packing property and low temperature sinterability.

It is already known well that sintering temperature of Barium Titanate can be reduced also by adding glassy materials having a low melting point. It is expected that sintering temperature will be further reduced by adding such an additive for low firing temperature to easily sinterable Barium Titanate obtained by the hydrothermal synthesis method. It is also expected that the amount of additives will decrease. Based on this expectation, the authors made measurements of the sintering and electrical properties of Barium Titanate powders produced by the hydrothermal synthesis method, the oxalate method, and the calcination method, respectively, with an additive for low firing temperature, after which they were compared with each other.

When mixel with 0.5 role? of an Amirine A, Carrum Titanate produced by the hydrothermal synthesis rether sintered at 1,000°C and exhibited sintering density of 5.81 g/ml; the cintered product from this mixture parsessed excellent electrical properties, i.e. its relative permittivety (at 20°), dielectric loss, Curie temperature, and relative permittivity (at the Curie temperature) were 2817, 1.4%, 122°C, and 3783, respectively.

In addition, it was found that an unique sintered product having a cubic system which cannot be obtained from Barium Titanate produced by either the calcination method or the oxalate method, can be obtained by using another additive (Additive B, C, or D).

2. Experimental Methods and Materials

2.1 Samples

The following 3 Barium Titanate powders were used as samples:

- (a) Barium Titanate powder (Ba/Ti ratio = 1.01) produced by the hydrothermal synthesis method
- (b) Barium Titanate powder (1.1um in mean particle size) produced by the calcination method
- (c) Commercially available Barium Titanate powder produced by the oxalate method

The Ba/Ti ratios and impurity contents of these powders were determined by fluorescent X-ray analysis and chemical analysis, respectively.

2.2 Additives

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The 5 additives shown in Table 1 were each added to

each powder sample in a specified amount. Mixing was carried out in a polyethylene pot containing zirconia balls and acetone overnight.

2.3 Molding

PVA in an 8wt% aqueous solution was added in a 0.8wt% ratio to each powder sample supplemented with an additive and granulated in an agate mortar, after which the resulting granules were sieved through a 35-mesh sieve. 2.2g of the sieved granules were then placed in a die (20 mm ϕ) and pressed under 1T/cm² pressure for 1 minute, yielding a green mold. The resulting green mold, after drying at 110 \sim 120°C overnight, was subjected to measurements of weight and dimension to determine its green density.

2.4 Sintering

Each resulting green mold was heated at a temperature rise rate of 200°C/hr and maintained at a specified temperature for 3 hours. During the heating, the green mold was maintained at 400°C for 3 hours to burn out the PVA. After the completion of the firing, each fired product was cooled down to a temperature reducing rate of 200°C/hr, after which the sintering density of the resulting sintered pellet was determined by Archimedes's method.

2.5 Electrical properties

The both sides of each sintered pellet was polished to a thickness of approx. 1.0mm, after which they were coated with Ag using an ion coater for the determination of electrical properties. Curie temperature was determined as follows: Each sample was placed in a chamber

adjusted to a heating rate of 0.5°C/min and subjected to measurements of changes in capacitance at 1KHz using an LCR meter 4332Å (HP). Both relative permittivity and dielectric loss at room temperature were determined at 1KHz using an LF impedance analyzer 4192Å (HP). Resistivity was measured at 20°C after 1 minute of application at DC 25V using a PA meter/DC voltage source 4140Å (HP).

2.6 X-ray diffraction analysis

Using an X-ray diffraction analyzer RAD-II (Rigaku Denki) measurements were made of the X-ray diffraction of each Barium Titanate powder and of each sintered pellet between 44° and 46° by CuKa radiation.

2.7 Grain size determination

The natural surface and if necessary, polished/thermal etched surface of each sintered pellet were observed by optical microscopy (magnification: ×1200) and scanning electron microscopy to observe its grain.

3. Results and Discussion

3.1 Powder properties

Table 2 shows the powder properties of each Barium Titanate powder. Figure 1 shows the TEM micrographs of the powder samples.

As shown in Table 2 and Figure 1, Barium Titanate powder produced by the hydrothermal synthesis method is the most excellent among the three powder samples in particle shape (spherical), particle size (0.lum), and particle size distribution (uniform). There is no significant

difference among the three in burity; because the hydrothermal synthesis method and the oxalate method are both wet reactions and the calcination method uses high-purity Barium Carbonate and high-purity Titanium Dioxide as the starting materials.

3.2 Sintering property

Figures 2 \sim 7 show the temperature dependence of sintered density for 3 kind of BaTiO₃ either with or without an additive. As shown in these figures, the Barium Titanate powder produced by the hydrothermal synthesis method is the most easily sinterable independent of whether or not an additive is added; its sintering temperature is $100 \sim 150 \,^{\circ}\text{C}$ and $150 \sim 200 \,^{\circ}\text{C}$ lower than that of the Barium Titanate powder produced by the oxalate method and that of the powder produced by the calcination method, respectively. Based on this finding, it is thought that the low temperature sinterability of the main raw material rather than the effect of additives is an important factor for low temperature firing.

Additive E is the most effective additive for low firing temperature, but its requirement for significant amount of addition has an adverse effect on the electrical property of the sintered product. On the other hand, Additive A makes it possible to perform sintering at 1,000°C even it is added in a small amount, thus having a less effect on the electrical property of the sintered product; it is thought of as the most excellent additive for low firing temperature.

3.3 Nerwy offication analysis

Figures 8 11 show the typical X-ray diffraction patterns of various sintered pellets and powders. The Barium Titanate powder produced by the hydrothermal synthesis method is cubic, while the Barium Titanate powder produced either by the oxalate method or by the calcination method is tetragonal due to calnation in the production process. The X-ray diffraction pattern of the sintered pellet of Barium Titanate powder produced by either the oxalate method or the calcination method shows the presence of tetragonal system independent of additive type and sintering temperature. On the other hand, the Barium Titanate powder produced by the hydrothermal synthesis method exhibits a unique sintering behavior. That is, when it is sintered in the absence of an additive, it changes in crystal system to tetragonal at approx. 900°C; when it is sintered in the presence of an additive, its sintering . behavior depends upon additive type, i.e., it changes in crystal system to tetragonal in the presence of Additive A or E, while it maintains a cubic system when sintered in the presence of Additive B, C or D.

3.4 Electrical properties

Figure 12 shows the typical temperature dependence of the relative permittivity of various sintered pellets. Table 3 shows the electrical properties of various sintered pellets at the minimum firing temperature for sintering. Based on the data shown in these figures and table, Additive A can be regarded as an excellent additive for low firing temperature. In addition, this additive produces

little shift in the Curie temperature of the sintering products; it is therefore conjectured that nearly all components of this additive are distributed in the grain boundary region.

4. Conclusions

Powder samples prepared by adding various additives for low firing temperature to Barium Titanate synthesized by various production methods were subjected to sinterability determination, crystal structure analysis for sintered pellet by X-ray diffraction, and electrical property determination, after which they were compared with each other. The results obtained are summarized as follows:

- (1) The Barium Titanate powder produced by the hydrothermal synthesis method was found to be more easily sinterable than that produced by oxalate method and calcination method even if additive were used.
- (2) It was found that the sinterability of Barium Titanate was the most important factor for low firing temperature even if additives were used.
- (3) Of the tested additives for low firing temperature, Additive A proved the most suitable to Barium Titanate sintering independent of production method type.
- (4) It was found that when some additives were used, a sintered pellet maintaining a cubic system can be obtained from Barium Titanate powder produced by the hydrothermal synthesis method.

Table 1. Additives

Additive	Content
A B	1 -0 (%)
Č	10 w 1% 5 w 1%
Ě	541%

Table 2. Preparation method of Balilo, and

Pe thad Preserty	Calcination Method (Solid Phase Reaction)	Oxaiste Method (Themai luminuosition of Barium Tilanty Oxsia- le)	Aydreuermal Symbolis
facticle shape	like crush stone	like crush stone	Sprerical
farticle size	coarser than 1 µm	steaut 0 . Sum	âbrout O. I⊯10a
Particle size distribution	very usee	wide	Therew.
BET Surface Area (w/g)	1	2	12
Bulk sensity (g/st)	0.83	0.72	0.59
teaurity (vt1)	0.01 0.01 0.02 0.014	0 - 0 1 1 0 - 0 1 4 0 - 0 1 4 0 - 0 1 4	0.01 0.014 0.014 0.014







Calcination Arthod

1

1

Ovalate Metho

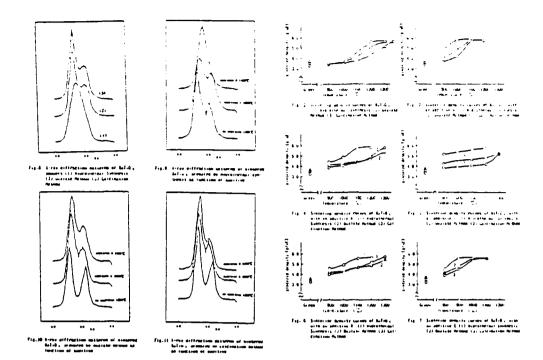
Rydrathernal synthesis

Fig 1. TEM photographs of Balifi, powders (X1000)

Table 3. Properties of Sintered Products

Preparation Rethod	1	Firing Tenueratur re (TC)	Sintered Jersilli (E/SI)	\$11e	Retative Permittivity		Curie Foint	Tand (%)	lesistivity (Ga)
	<u> </u>	A (C)		(mm)	ಇರ	W	(5)		1
Hydrothermal Synthesis	10	1200	5.10	2.1	:235	6130	125	0.01	1.9×10"
Jynua's is	1	1000	5.82	0.8	2317	נאונ	122	1.40	2.1×1013
		1100	5.78	0.41	1223	2507	127	3.10	6.0×10"
	С	1100	5.□	0.31	1633	1023	112	1.2	5.7×10 4
	D	1100	1.20	0.31	1218	2225	110	3.27	3.8×10 ¹⁰
	ť	200	5.C4	11.5	E 3	Z.Z.	120	1.70	1.0×10"
Usalate Inches	40)	1300	5.63	4.3	3147	10123	120	3.35	8.7×1011
		1100	5.78	2.2	2030	4845	123	2.84	1.5×10*
	1	1300	5.27		amo	l be sin	Lered		
	c	1330	5.45	1.0	1113	E	133	3.21	4.4×10**
	0	1200	5.53	2.8	1712	CCC1	iΒ	4.87	2.5×10 4
	E	1000	\$.70	1.3	1874	4481	144	18.0	2.1×10 *
Culcination Sethod	R)	1220	5.84	1.7	2018	3023	171	1.54	1.0×1019
	A	1100	1.25	12.0	21131	C:0	110	1.12	2.2×1013
	B	1300	5.80	2.0	1771	ಮಾ	130	2.86	1.0×10 ¹⁴
	C	1200	1.2		canno	be 110	ue red		
	0	1320	5.81	2.5	1477 j	5740	132	3.04	2.3×101
	E	1000	5.54	12.8	736	101	144	3.47	8.6×10 *

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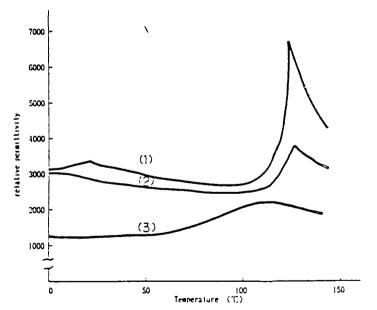


Fig. 12 Temperature dependence of relative nermittivity for sintered BaTiO $_2$ products propared by hydrothermal synthesis (1) without an additive (2) with an additive A (3) with an additive 0

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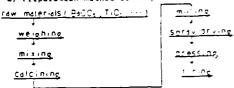
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CURAMIC COMPONENTS MEG DIVISION TOR COMPORATION

Table 1. at Composition of sameles imples

CAH-IND	245	ا ، • " به ا		
4	i i	113 1	a =	1
ä	772	1.0 [30.	
	1 3 7	2 3 7	J 77	<u> </u>

b) Preparation method of samples



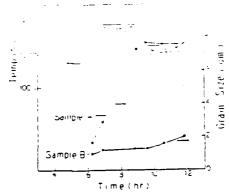


Fig.1. Change of grain sizes of sample A and B by Rapid Cooling Experiment

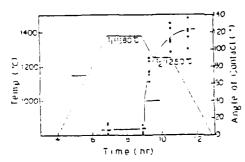


Fig.2. Angle of contact by Rapid Conling Experiment (sample 8)

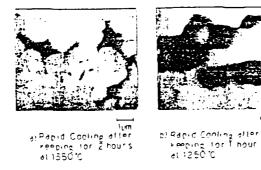
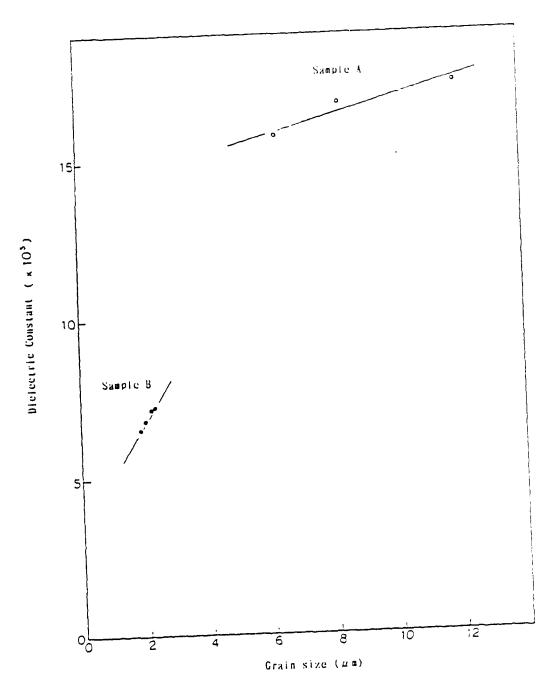


Photo 1. Microstructures of sample B observed by SEM (Composition Image)



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Fig. 3. Relation between dielectric constant and grain size

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MACHINING OF FZI, FI, AND (Mn, Zn)Fe204 CLRAMIUS

BY LASER-INDUCED CHEMICAL EIGHING

T. SHIOSAKI and A. FAWABAIA

Department of Electronics, Faculty of Engineering,

Kyoto University, Kyoto, 606, Japan

ABSTRACT: Loser-enhanced chemical etching of PbTiO3. PZT and (Mn-Zn)-ferrite ceramics is reported. The KOH solution of 10 mol/1 is suitable for the laser enhanced intergranular etching of the PbTiO3 and PZT with depth etching rate higher than 100 µm/s in the initial laser irradiation period of Ar+ laser of 1W. The KUII and NaOII solutions are also suitable for the intergranular etching of (Mn-Zn)-ferrite. The $\rm H_3PO_4$ solution of 6 mol/1 is suitable for the laser enhanced trans-granular etching of (Mn-Zn)-ferrite with the depth etching rate of about 10 µm/s in the initial irradiation period of an Ar + laser of IW.

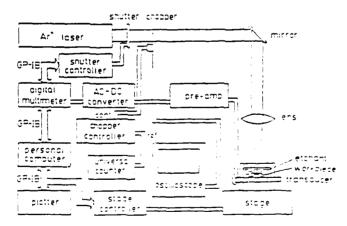


Fig. 1. Experimental setting for laser-induced onemical economy. The photo-accusting emmission detected by the transducer is used for the automatic forms indicated for the gonvex lens is all quarts with a conductivity of 3 mm.

Table 1. Securitity of PET and Philo, catables in values accounts

	PZT	Fellog	TIN Alterna
Cite Lampi	0.019#(mg/10min)	0.01221mgr 10mm1	n.Onn?#img/itimtm
Adre (Own))	0.0041	0.0015	0
Machillant1	0.00Rt	0.0013	0.0075
%,P0_(30%)	0 0425	n oris	0 0011
H150-(932)	0.067	Q.027A	0
MCL(35X1	0.69	0.030	0.001
1840 , (#01)	0.25	0 047	0.001
(C0:M1, (02)	0 014	0.0056	0.004

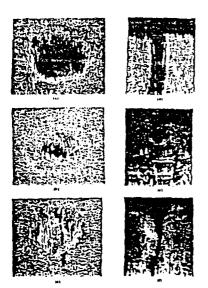
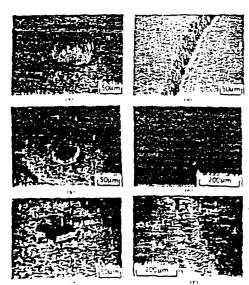
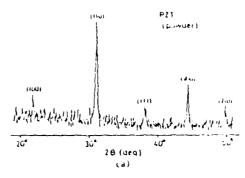


Fig. 2. SFM photographs of laser etched samples of modified Potio, ceramics using 1M incident Ar Ion isers promet. Holes processed with 5s exposure in (a) inmoi/1 Pril. (b) air and (c) water. Slots in (d) 10moi/1 ROM. (d) its and (f) water canned at Amm/min.



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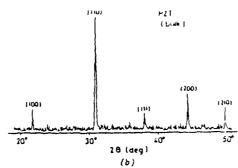


Fig. 4 The X-ray diffraction patterns of the powders (a) and bulk (b) of PZT. The PZT powders are collected from the etchant.

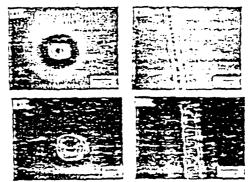


fig. 3. SER encouncements of large extense on their a stance which places increased with a place of the stances as the set and the wester. Show it is not account of the set and the wester. Show it is not account of the set of the s

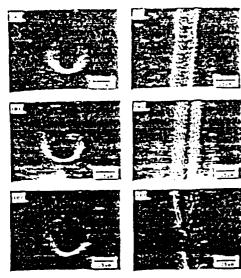
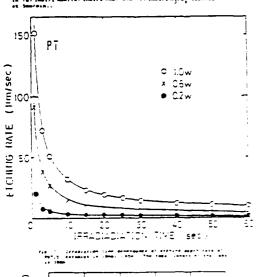
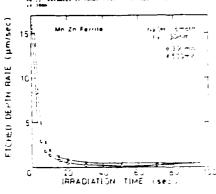


Fig. 6. SEM percentage of lower action (FM. En/Fe.) coronies using 135mm includes lower percent in the 12mm includes lower percent in the 12mm includes lower lowe





. Fig. 4. , constructed in the department of the record segacy $\rho_{\rm spin}$ at the defining record on the squarement

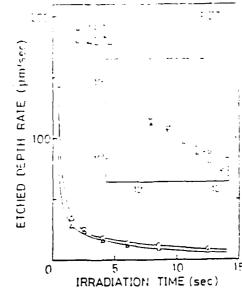


Fig. 2. The relation perween the leaver-induced etening rate and the leaver irreduction time. The leaver output is in one 80m non-street as its limit.

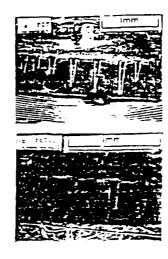


fig.15. The appearances of houses of ceams are all full a land Potics, who terapine using mount form lase lower though processed with just the exposure of community

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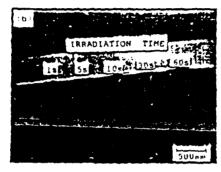


Fig.11. The appearances of holes of laser ctched (Mn.Zn)Fe₂O₄ ceramics using IW incident laser power. Moles processed with 1 to 60s exposure in (a) 6mol/1 NaOH and (b) 6mol/1 H₂PO₄.



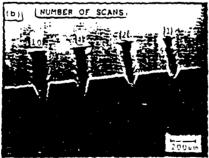


Fig.12. The appearances of slots of laser etched 'Mn.2n'Fe,O, deramics. Slots made with 1 to 10 scannings using inclident laser power of 1% in 5mol/1HaOH (a) and 0.5W in 5mol/1H₃PO₄ (b) scanned at 6mm/min.

SYNTHESIS AND PROPERTIES OF ALKOXY-DERIVED Zn_XTi_ySn₂O₄ S. HIRANO, T. HAYASHI and A. HATTORI NAGOYA UNIV., JAPAN

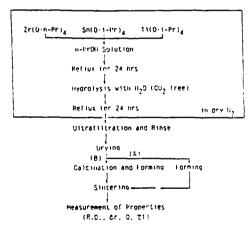
Introduction :

Many kinds of dielectric materials have been developed for microwave applications. Among them, the compound in the system 2r-11-5n-0, $2r_x T1_y Sn_y O_4$ (x+y+z=2). Is known to have a high dielectric constant, a low dielectric loss and a low temperature coefficient of resonance frequency. The compound has been sintered with the sintering aids like ZnO, NiO, Fe₂O₃ and La₂O₃.

Objectives :

- Preparation of monosized unagglomerated spherical particles by controlled hydrolysis of metal alkoxides
- 2) Sintering behaviors without additives
- 3) Dielectric properties (&r, Q, Tf) of sintered bodies without additives

Experimental

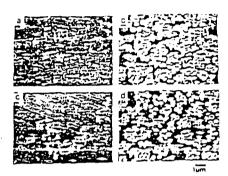


Results

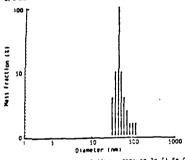
Effect of Hydrolysis Conditions on Porticle Size and Marahalagy of As-preziditates, $2r_{c,po}TiSn_{c,po}u$

Cons.(mp]/])	Hydrolysis	Porticle Size(ut.)	tiorphology
0.05	room temp.	< C.1	Irregular
G. C5	reflux	0.3-0.4	somerical
0.025	room temp.	0.1-0.2	senerical
0.025	reflux	0.3-0.4	spherical

⁽As-precipitated powders were omorphises)



SEM of as-precipitated powders
a) 0.05moi/1, room temp. b) 0.05moi/1, reflux.
c) 0.025moi/1, room temp. d) 0.025moi/1, reflux.



Particle Size Distribution of Alkoxy-derived 2r_xTi_ySn₂Q₄

Effect of Processing on Sintering of 2r_{0.80}TiSn_{0.20}Q₄

Particle		Relative	Relative Density (%)		
Size (um)	Process	Green 2007	Sincered Bod		
3,1-3.2		49	96		
0.3-0.4	A	55	92		
0.3-0.4	8	15	ŧo		

*Process A: As-precipitates = Consolidation = Crystallization(600°C,5nrs) = Sintering(1600°C,7nrs) Process 8: As-precipitates = Calicination(600°C,5nrs) = Forming = Sintering(1600°C,3nrs)

Effect of Processing on Sintering of Zrg. 1071500.3004

Process*	Fetative	Density (%)	- Shrinkage
Process	grach Bods	Sinteres Das	• • •
4	45	95	23.0
•	45	82	14.5

^{*} Amount of water , 4 times the eau).clent amount required for hydrolysis

Densities and Phases of Sintered Bodies

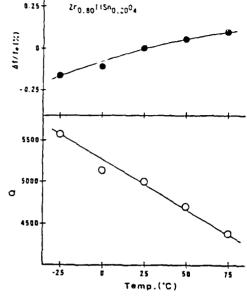
	Bull Den	(ft) (q. cm²)	
1	Green Body	Sintered Body	Phases
0.20	2.92 (55)*	5.13 (99)*	Zrg 40115hg 2004
0 ! 0	2.85 (54)*	5.15 (98)*	Zrg zglisng icoa
0.40	2.99	5.10	Zritijsnjoj, (tilsn)0

* Relative Density (%) 1600°C.3hrs in 0,

Properties of Bodies Sintered at 1600°C for 3 hrs

2	·.D.(%)	٤r	0	Tr(ppm/10)
0.00	100	46.2	2700	71.8
0.20	98	40.0	5000	2.6
0.30	98	37.7	5200	-10.6
0.40*	~-	39.6	5000	45.2

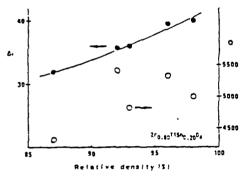
 $Zr_xT1_ySn_zO_4$. • not single phase at 10GHz



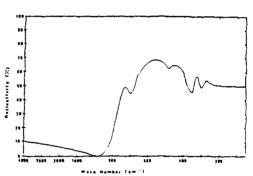
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Temperature dependences of Q and Af/f



Changes of gr and 0 with Relative Density of Sintered Body



Conclusions

- 1) Monosized unagglomerated spherical particles of $Zr_{0.30}TiSn_{0.20}O_4$ were synthesized by controlled hydrolysis of metal alkoxides.
- 2) Dense sintered bodies of ${\rm Ir_XTi_YSn_2O_4}$ were prepared by sintering consolidated as-precipitated particles without sintering additives.
- 3) Dense sincered body of $2r_{0.80}^{-1} Sn_{0.20} O_4$ showed good properties (6r=40.0, 0=5000 and Tf=3 ppm/ O_4) at 10 GHz.

EFFECT OF AGGLOMERATED PARTICLES ON PROPERTIES OF CERAMIC GREEN SHEETS.

Tainotsu Ueyama, Naoya Karieko and Yoichi Machii

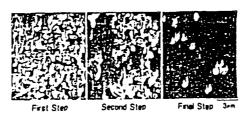
Shinodate Research Laboratory. Hitachi Chemical Co., Ltd. 1380-1 Tarazaki, Katsuta. Ibaraki, 312 Japan.

Table 1 Typical composition of Al₂O₃ green sheets

weight parts
100
6
3
Proper
Quantity

Table 2 Typical composition of BaTiO₃ green sheets

Material	weight parts
BaTiOs	100
Binder (Poly methyl methacrilat)	124
Plasticizer (Butyl Benzji phthalate)	1.4
Solvent (Chlorinated Hydrocarbon	Proper
& Keton Mixture)	Quantity



POSSESSION PROFESSION

Fig.1 Applomerated particle size of Al₂O₃ powder in slurry

Agglomerates size was measurured by SEM on sturry sample diffuted and dispersed with solvent and 28KHz ultraspine wave treatment

New advanced process, agglomerates Al₂O₂ powders were gradually pulverized during Mixing, and the particle size was finally reduced to primary particles.

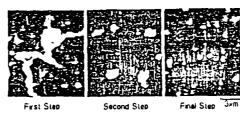


Fig 2 Agglomerated particle size of BaTiO₂ Powder in slurry

in conventional process, agglomerated particles of barium titanate, were almost not pulverized, and agglomerated particle diameter was about $4.6 \, \text{μm}$

On the other hand, in the new advanced process, assumerated particles were pulverized sufficiently, and the diameter became under 1 0 μm , which was nearly equal to primary particle diameter of 0.6 μm

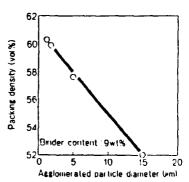


Fig. 4 Relationship between agglomerated particle diameter and packing density of AQO₃ green sheet

The smaller the agglomerates diameter, the higher the packing density of Al₂O₃ powders, particularly, when agglomerates become the primary particle packing density of Al₂O₃ powders reaches the maximum value of 60 3 vol.%

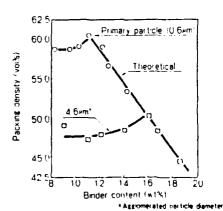


Fig.9 Relationship between binder content and packing density of BaTiO₃ green sheet

The smaller asslomerated particle diameter and/or binder content was, the higher packing density of barium titanate powders became

Particularly, when assignmented particle diameter was below 1µm, packing density reached the maximum value of 60 4vol% at the binder content of 11.1wt%.

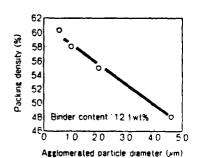


Fig.7 Relationship between agglomerated particle diameter and packing density of BaTiO₃ green sheet

When agglomerates are pulverized the packing density gradually increases, and reaches the saturation value of 60.4 vol% when the size of the primary particles is attained. This value is almost equal to the cacking density of 60.45 vol% calculated with monosized powders cast without pressure.

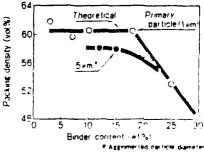


Fig.10 Relationship between binder content and packing density of A&O, green sheet

The smaller the agglomerates diameter and or binder contents, the higher the Dacking density of A₁(2) conders Especially, when binder content was 18 weight's Dacking density reaches the saturated value of 60.3 yol%

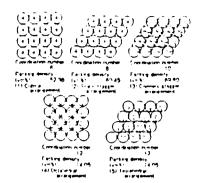


Fig.5 Packing forms of monosized balls

when monosized powders are packed without external force like doctor blading process, it can be presumed that the minimum coordination number is 8.

Therefore, theoretically, the maximum packing density of monosized powders in green sheets is 60 45 or 1%.

60.45vol%
The maximum backing density of barium titanate powders, which was obtained in this work, was nearly equal to this theoretical backing density of monosized powders.

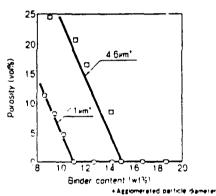


Fig 11 Relationship between binder content and porosity of green sheets

When binder content increased porosity of green sheets decreased linearly

The binder content at which percept reached Oxors became smaller when assignmented particle drameter became smaller.

This value was the same as the content at which Breen density reached the maximum value

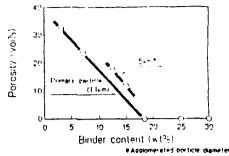


Fig.12 Relationship between Binder content and Porosity of AUO Green Sheet

Conclusions

- 1 Green sheet density is largely effected by the assignmental size.
- Green sheet density increases with the decrease of the size of agglomerates, and reaches the saturation value when the agglomerate size equals the primary particle size
- 3. Packing density in the green sheets increases at decreasing agglomerate size, and reaches the saturation value of 60.2 volfs of Al₂O₂ powder and 60.4 volfs of BaTiO₂ powder respectively, the size of agglomerates reaches the primary particle size.
- 4 The saturation value of 60.2 vol% of Al₂O₃ and 60.4 vol% of BaTiO₃ powder is well matched with the packing density of 60.45 vol% corresponding to a coordination number 8 for monosized particles in single stagger arrangement.
- 5 Especially, incase of BaTiO, green sheet, when applicates are bulverized backing density reaches a maximum at a definite binder content, and decreases when the binder content deviates from this level, either downward or upward.
- 6 The packing density of BaTiO₃ decrease which occurs when the binder content in the green sheets is too small is assumed to derive from a weaker bonding force of the binder which incompletely fills interparticle yords.

Sinterability of High-Packing Density BaTiO₃ Green Sheet

> Tamotsu Ueyama *Shozo Yamana & Naoya Kaneko

Simodate Research Laboratory Hitachi Chemical Co., Ltd. 1380-1 Tarazaki Katsuta. Ibaraki, 312. Japan

Table 1 Characteristic of BaTiO₂ powder*

Item	density	specific surface area	Average particle Diameter
Unit	9/cm²	m²/9	μm
obser	6 0 1	2.52	06

Item	Chemical composition Ba Ti Pd Zn Nb Bi Co Si Min Al Sr Ni
Unit	96
obser-	69 18 75 35 2 14 1 10 1 09 0 60 0 27 0 17 0 03 0 03 0 03 0 01

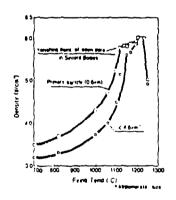
. TAMTRON CERANICS

As delectric material, BaTiO, was used in this work. Table 1 gives the chemical composition of BaTiO, powder. Dielectric green sheets were produced by the doctor blade process. Samples were sintered in the raise 700–1300c in atomosphere. The packing density (Po) of the preen sheets.

was calculated by the equation (1):

$$\rho_0 = \frac{\rho_0 \times \epsilon}{\rho_0} \qquad (1)$$

 $\ensuremath{\textit{Pg}}$. Green sheet density $\ensuremath{\textit{Pd}}$. Density of dielectric powder Xd , Weight component ratio of dielectric powder



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Fig. 1 Relationship between the firing temperature and fired density.

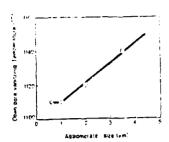
700~3170C . Density increases rapidly and exponentially Tile open pores of a sintered body vanish at 1170C in the green sheets is 60.4 vol75.

2) 1120~1200C : Density slightly increases toward the saturated density

3) 1700~1210C . Increses discontinuously toward the saturated density

4) 1210~1240C. The density reaches the saturated value 60 o cm³ at 1210C and dose not change up to 1240C.

The density decreases rapidly and open pores



THE PROPERTY OF THE PROPERTY O

Fig. 2 Relationship between the aggiomerates size of BaTiO₁ and vanishing temperature of the open pore in sintered body

The smaker the agglomerates size is, the lower the hung temperature is. This means that sinterability is improved when agglomerated particles are pulverized.

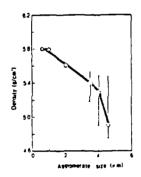


Fig. 4 Relationship between the agglomerate size and fired density which was fired at open pore vanishing temperature.

The density of a sintered body increases rapidly when applomerated particles are powerized in to small applomerate size and at the primary purticle diameter. Saturation is carried out at the maximum value \$8.9/cm³.

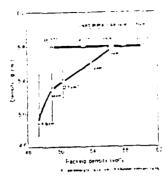


Fig. 3. Relationship between the packing density and fired density when was fired at open pore vanishing temperature.

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Shoon assessing are coreed production of a sections

Circle marks in the figure shown the backing density changed by changing the amout of bilder using preen sheets which applomerated particles are ouiverized into primary particles. Suffix numbers shown the amount of binder. On the other hand, source marks shown the backing density changed by changing apploherate. Size with the bilder fixed at the value 11 wt%. Suffix numbers shown apploperate.

CONCLUSIONS

- The fired density of BaTiO, varies greatly within five temperature ragions.
- When the egolomerated size in a preen sheet is small, the temperature at which open pores vanish is low.
- When applomerated carticles are dispersed into parimary particles, the fired density of BaTiO₃ at notimum temperature becomes a fixed value of 58 g/cm².
- 4 This value does not change when the amount of binder in a green sheet varies and when the packing density changes from 49-604% The reason is that the packing density becomes the same value of 604% after burning off its binder.
- 5. The fixed density changes as applomerate, size changes. For instance, it becomes 19 pricm, when the applomerates size of BaTiC₁ is 46 km. This value becomes 54 grcm, at 35 km, and 55 grcm, at 2 km. The estimated reasons are as follows: cores caused by steric hydrance among applomerated particles and poles in applomerated particles are left in the sintered body at the temperature that open pores vanish.

AN INVESTIGATION OF THE LOW VULTAGE FAILURE MECHANISM IN MULTILAYER CERAMIC CAPACITORS

C. JOHN BRANNON AND H. U. ANDERSON DEPARTMENT OF CERAMIC ENGINEERING UNIVERSITY OF MISSOURI-ROLLA ROLLA. MO 65401

THIS WORK SPONSORED BY
THE OFFICE OF NAVAL RESEARCH

LOW-VILLIAGE FAILURE

LON-VOLTAGE FAILURE IN MULTILATER CERAMIC CAPACITORS IS DEFINED AS INSULATION RESISTANCE FAILURE OCCURRING WHEN THE CAPACITOR IS BJASED FAR BELDW ITS RATED VOLTAGE. TYPICAL BIAS VOLTAGES FOR LOW-VOLTAGE FAILURE ARE 1 OR 2 VOLTS. TWO CONDITIONS MECESSARY FOR LOW-VOLTAGE FAILURE ARE 1 HE PRESENCE OF MOISTURE AND THE EXISTANCE OF STRUCTURAL DEFECTS SUCH AS CRACKS OR VOLDS EXTENDING FROM THE SURFACE OF THE CAPACITOR THROUGH AT LEAST TWO ELECTRODE LAYERS. WHEN EXPOSED TO A MIGH BIAS. CAPACITORS EXPERIENCING LOW-VOLTAGE FAILURE TEND TO RECOVER, OR REGAIN THEIR ORIGINAL HIGH INSULATION RESISTANCE LEVEL. CAPACITORS HAY ALSO RECOVER AFTER A MODERATE MEAT TREATMENT.

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EMPRENTY. THE MOST POPULAR THEORY OF COMPORTAGE FAILURE CONCERNS
THE GROWTH OF ACTALLIC BERRETES OF ELECTRODE MATERIAL THAT BRIDGE THE
SAP RETWERN THE ELECTRODES. THESE DEPORTES CREATE A COMPORTION PATH
RETWERN THO ELECTRODE LATERS. THUS PRODUCTING A SHORT AT LOW POLITICES.
THE DEMORTTE IS FORMED WHER ELECTRODE MATERIAL IS BISSOURY IN WAITE
WHICH HAS COMBERSED IN THE PRESENT DEFECTS. THE DEMORTTE THE BROWS
ALONG THE DEFECT STHER BY ELECTROCEMOLITION DO BY PRECEPTIATION.
HERE ESPOSED TO A RIGH STAS. THE ELECTRODE IS PAPORIZED AND THE FAILURE
CLASSES.

A SECOND PROPOSED RECHARISK OF LOW-FOLTAGE FAILURE HAS TO DO WITH ACCELERATED ACTING DOT THE DISCRETATE CHARGE SETTING HER ELECTROSES.

CARTELL-FRANCE TRANSFORMATIONS OCCUR IN THE DISCRETANCE CONTINUE A DESIGNABILION ACCOMPANIED BY A SUBSECULAR INCRESSE IN CONTUNCTIVITY.

APPLICATION OF A WIGH FOLTAGE PRODUCES A RESTRUCT METER ACLORS

THE BISLECTRIC TO RETRANSFORM TO TES CRIGINAL STRUCTURE.

CABLES MEALS: SBULLWIGE

- ALL CAPACITORS WERE SUBJECTED TO THE METHANOL TEST. THE METHANOL TEST WAS PERFORMED AS FOLLOWS.
 - 10 YGC was applied to the capaciton and artem is seconds the learning cumpetur (1) was measured.

- 2. Inc capacitor was then immersed in methanoc por 30 minutes accounts the nethanoc to penetrate into craces and open population.
- Inc capacities was removed from the nethanol and allowed to bet on a fissure to neminize the residual methanol left on the subject.

7

4. SIEP I HAS REPEATED IMMEDIATELY AFTER DAYING AND (1_2) was measures.

A capacitor was considered to make failed the methanol test if l_2 was an order of nagnitude on more greater than l_3 .

- 2. STRUCTURAL DEFECTS IN THE FORM OF CRACES WERE INTRODUCED INTO THE CAPACITION. THIS WAS ACCOMPLISHED BY THERMAL SHOCKING THE CAPACITIONS. SPECIMENS WERE HEATED TO 575°C AND ALLOWED TO SOAK FOR 1 HOURS. SPECIMENS WERE THEN IMPOINTELY OWENCED IN LIQUID TO SAKE FOR 198°C, ACRITYMING A THERMAL GRADIENT SUFFICIENT TO INDUCE TRACES EXTENDING FROM THE CURFACE THROUGH THE ELECTRODY LATERS. BUT INSUFFICIENT TO DIMERIEST DAMAGE THE CAPACITOR OF ITS CLECTRICAL PROPERTY.
- Specimens were subjected to a variation of the standard 85/85 test
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 852 RM. The attrophycist was varied as minoral pay is mounts well and
 windows pay. Taxishal tests shad made with rollacts set at 0.5
 8.0 (1.5) 2.0 5.0 10.0 20.0, who how how the standard set.
- SPECIMENS SUBJECTED IN MOTHER MARKETON OF THE STANDARD ES 25.
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- 5 THE STANDARD 65-25 TEST WITH STANDARD I 5 NDC BIAS WAS PERFORMED ON 20 SPECIMENS FOR A PERIOD OF LZ DAYS. WE TWEEL IS WERE INCOCKED AND 5 WERE UNCACLED CONTROLS. THE STRONGER WAS DRY FOR THE PRINT AND LAST DAYS OF THE TEST AND MAS MAINTAINED AT 852 RM. THE MESS OF THE TIME.
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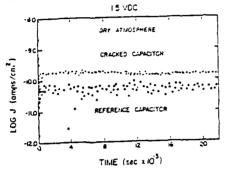
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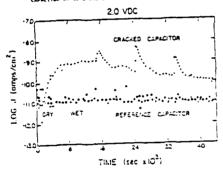
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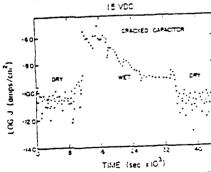
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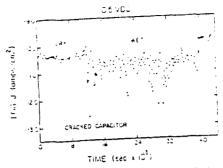
PLOT OF THE LOGARITHM OF THE LEARNING COMMENT DERSITY VS. 17ML IN-1670NUS FOR MOTH & CRACKED AND AN UNCHACKED CAPACITOR AT 35°C AND 1.5 VDC IN A MEY ATMOSPHERE.



PLOT OF THE LOCARITHM OF FIRE LEARNER CHREET DEWSITY VI. TIME IN TECCHOS FOR SOTH A CRACETO AND AN INCRECED CAPACITY UNDERGOING THE 63/35 2.0 VEC TEST WITH VARYING ATMOSPMENT.

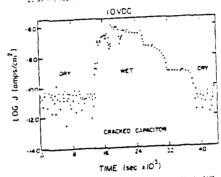


PLOT OF THE LOCARITHM OF THE LERBALE CURRENT DENSITY US. THE IS SECOND FROM A CHARLED CAPACITOR WHEREGOING THE 35/25 1.5 YEC TEXT WITH VARTING ATMOSPHERE.

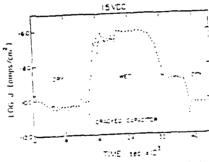


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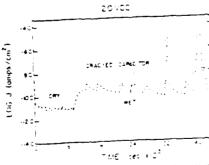
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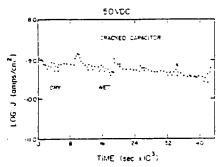
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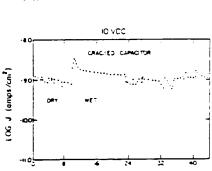
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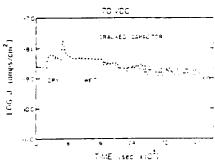


PLOS OF THE LOGARITHM OF THE LEARANG CHREST DERISTER VS. "LIME IS LECORDS FOR A CRACKED CAPACITOR UNDERGOING THE 35 RS. S. U. VIC. TEST WITH HARTING ALMOSPHERE.

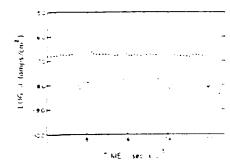


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- 1) RESIDES AT GRAIN BOUNDARY
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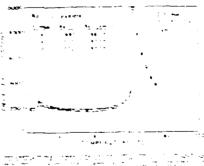
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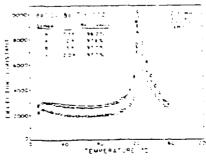
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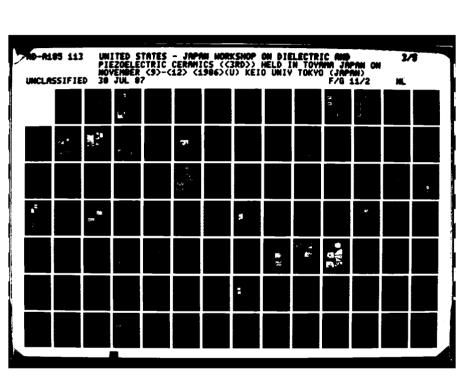
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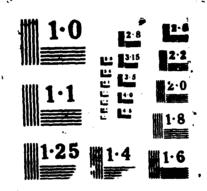
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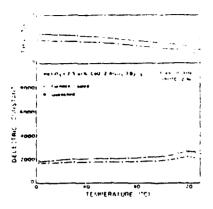
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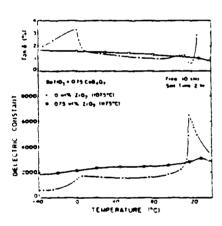




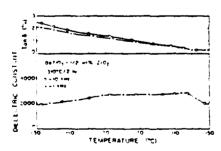




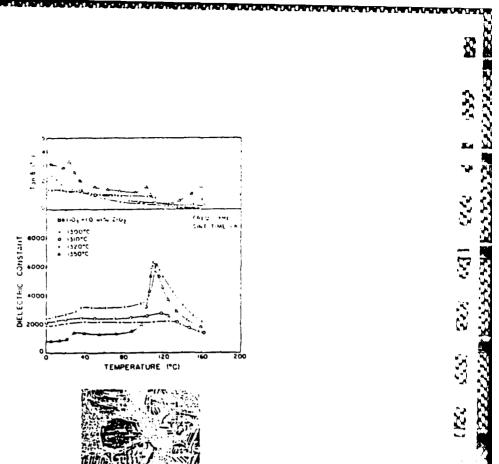
DIELECTRIC CONSTANT AND TAN 5 PROFILE AS A FUNCTION OF TEMPERATURE FOR Ca Alborate MODIFIED BTFO3 SAMPLE.



DIELECTRIC CONSTANT AND TAN 5 PROFILE COMPARING Callorate and ZrO2 MODIFIED BalliO3.



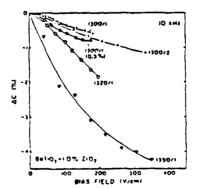
DIELECTRIC CONSTANT AND TAN & CHANGES WITH TEMPERATURE FOR BATIO1 SAMPLE AND GRAIN BOUNDARY Z-O2 PHASE.





SEM PHOTOMICROGRAPHS COMPARING MICROSTRUCTURES FOR BATIO3 AND MODIFIED WITH LO WT% Z/O2 (1300*C/211R).

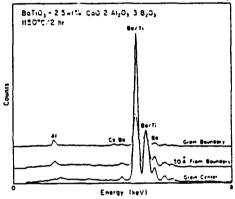
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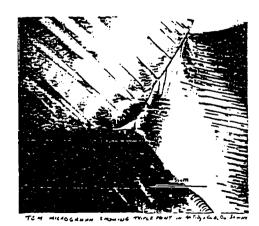
PERCENT CAPACITANCE CHANGE WITH DC BIAS FIELD FOR Z-O2 MODIFIED BATIO3 AT DIFFERENT SINTERING TEMPERATURES.



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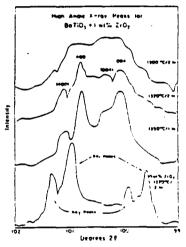


EDS SPECTAN OF GHAIN BOUNDARY
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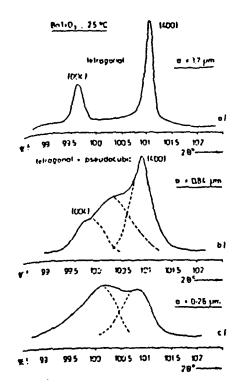
HIGH ANGLE X-RAY DIFFRACTION PEAKS SHOWING SUPPRESSION OF TETRAGONAL PEAKS IN ILL FIO3 WITH Calborate AND ZrO2 ADDITIONS.



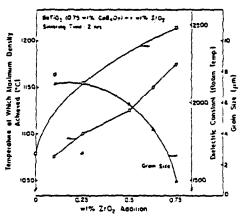
HIGH ANGLE X-RAY PEARS SHOWING DEVELOPMENT OF TETRACONAL PEARS IN BATIO1 WITH ZFION-MIGRATION FROM GRAIN BOUNDARIES.

TABLE 3. EFFECT OF FLUTES ON INC ATTAL BATTO OF BATTO,

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71		wo sm	11116	
(1350°C/100)				
+ er2	1709.0021	1 997	4 810	1 805
7 -12	1700.0021	4 005	1 075	1 005



Change in BATIO, STALLETURE WITH GLAIN SIZE (ARLT)



PLOT SHOWING VARIATION OF GRAIN SIZE, DIELECTRIC CONSTANT AND MAXIMUM DENSIFICATION TEMPERATURE WITH ZFO2 CONTENT.

SUMMARY

ZRO2 ADDED TO CJB407 FLUXED BaTiO3 (< 1 WT%) PREFERENTIALLY RESIDES AT THE GRAIN BOUNDARIES. THIS CONSTRAINS DISCONTINUOUS GRAIN GROWTH, SO THAT POLARIZATION IS ESSENTIALLY CONTROLLED BY THE GRAIN SIZE.

was the transfer of the first of the state o

CaO-2AI2O3-3B2O3 ADDED TO BaTiO3 SUPPRESSES GRAIN GROWTH AND THE TETRAGONAL TO CUBIC TRANSITION, GIVING A HIGH DIELECTRIC CONSTANT LOW LOSS, AND LOW D.C. SENSITIVITY. THIS MAY BE PARTIALLY ATTRIBUTED TO THE FINE GRAIN SIZE (< 1µm) PRESENCE OF AI3+ IONS IN THE LATTICE.

THE ABOVE GAVE A FLAT DIELECTRIC CONSTANT/TEMPERATURE PROFILE WITH YSR CHARACTERISTICS.

11.5

2

-2

Barium Titanate-Based Dielectric For MLC's With High K and Low Firing Temperature

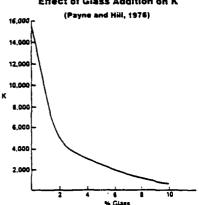
I. Burn & M. T. Secaur

E. I. Du Pont de Nemours & Co. Photosystems and Electronic Products Department **Electronic Materials Division**

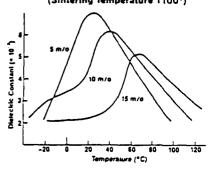
Low Cost Electrode Technologies For High K Dielectrics (Z5U)

	Electrode	<u> </u>
• Low-fired BaTiO,	<u></u> 270% Ag	6000
• Pb Injection	Pb	8000-10,000
Base Metal	NI	8000-10,000
PhO-based Relaxors	185% An	9000-15 000

Effect of Glass Addition on K



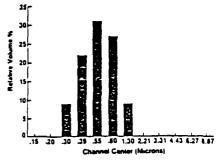
Influence of PbO on TCC (BaTiO₁) (Sintering Temperature 1100°)



Low Fire BaTiO, Technology: Principles

- Small amount of glass-forming oxides (no fluorides)
- A/B Stoichiometry
 - System approach (ceramic + flux)
 - Grain growth control
- Fine particle size powders (≤1 μm)

BaTiO, Particle Size Distribution



Dielectric Tape Formulation

Binder Mix Formulation

	WT. %
Du Pant 5200 Binder Solution	28.3 (8.5% resin)
Monsanto Santicizer 160 (Butyl Benzyl Phthalate)	2.1 (2.1% resin)
1,1,1-Trichloroethane	66.1
10% Hercules Polypale Solution in Isopropanol	1.50 (0.15% resin)
Total	100.0 (10.75% resin
Mill Batch	
Ceramic Powder	100
Binder Mix	65

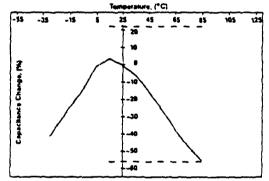
XL103 Firing

- Bakeout
 - 400°C (min)
 - 750°C (bisque)
- Sintering
 - 1100°C (2012°F); 2 hours
- Setters (optional)
- Containers (no sand)

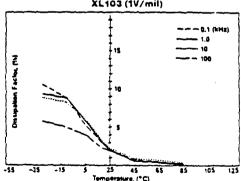
XL103 Z5U Dielectric Electrical Properties

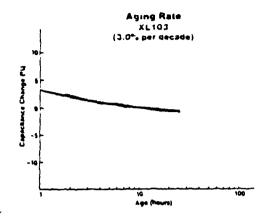
Firing Temp. (°C		1 VRMS	AC@85°C	R±C 25°	RxC B5'
(0.5 uF 22	25 Size 5 A	ctive Lay	era)		
1100	19,000	1.00%	-61.9	11500	2100
1080	9,700	1.20%	-55.9	10900	2000
(0.17 μF 1	209 Size 10	Active L	ayers)		
1100	10,000	1.30%	-56.9	10000	1000
1080	9,300	1.40%	-54.5	10000	1000

TCC XL103 K • 10,000 ±500



DF vs. Frequency XL103 (1V/mil)





PARTICIONE DE LO LO COMO DE LO COMO DE LA COMO DE LA COMO DE LO C

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XL103 Reliability

bwv

>600 VDC/mil

Life Test

- 100 V/mil, 85°C, 1000 hours
 - OF/30 (5 layer 2225)
 - No degradation
- 200 V/mil, 125°C, 24 hours
 OF/ca. 100 (5 layer 1209)
- SQ V/MII, 85°C/852 RH, 1000 hours
 NO degradation (5 layer 1209)

Fracture Toughness

- Kic - 0.9 MPa.mi

Summary

Low Fire BaTiO, Based Dielectrics

- Low PbQ content (Sale and easy to process)
- · Proven reliability
- · Preferred for SMT
- . Now available with Competitive K

3

ELECTRICAL CONDUCTION

IN BaTIO3-BASED CERAMIC

bγ

LC Burton and HY Lee

Virginia Polytechnic Institute & State University

Biacksburg, VA 24061 USA

CONTENTS

- Electronic Current and Ionically Induced Current
 - a. Model
 - b. Experimental

Region 1: Stable electron current

Region 2: fortically induced current

- 2. Role of Grain Boundaries
 - a. Evidence in I-V and u(T)?
 - b Voltage biased impedance
 - c. Significance of grain size
- 1a Ionically Induced Electron Current Model



Con ≈ total O charge arriving at anode per sec

But was a way of 0' moves by hopping and

$$\frac{dV_0}{dt} = \frac{J_{00}}{2gw} = \frac{J_{10}}{2gw} = \frac{2gv}{dt} = \frac{dV_0}{dt}$$

Also $J_{V_0} = u_{son} r = 2q(V_0) \lim_{N \to \infty} \frac{v}{w}$ (v = vollege)

urrent will be sufferdiwing

Thus
$$2qw \frac{dV_0}{dt} = 2q \mu_{00} \frac{v^2}{w} |V_0|^2$$

4444444 Printerial Rainesse Renewals See Renewals See See See See Compressed Research

This integrates to
$$\{V_0^-\} = \{V_0^-\}_0^- \exp\left(\frac{\mu_{\text{opt}}^-v^0}{w^2}\right)$$

Use
$$n = n_0 + 2|V_0|$$
 , $n_0 = 2|V_0| h_0$.

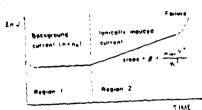
to obtain
$$n = \frac{n_0}{2}[1 + \exp{\beta(t-t_0)}]$$
 . $\beta = \frac{\mu_{\text{abs}} v}{v^2}$

at fixed w and v

Generic Electron Current Curve

$$J = an \mu_0 \frac{\sqrt{m}}{w} = a \mu_0 \frac{\sqrt{m}}{w} \frac{n_0}{2} (1 - e^{2(1 - k_0)})$$

ım > 1)



tioles

- Currents expected to deviate at pediming and end invalidation william during and linal tailure.
- 2 vos may not equal 2 , , , ue t other Hansport mechanisms
- 3 Mayor and Me are also expected to

For idelines, τ_1,τ_2 at lemperatures, τ_1,τ_2 and voltages, \forall_1,\forall_2

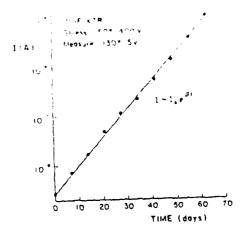
$$\tau_1 = \frac{w^2 e^{\frac{c_1 + c_2}{2}}}{\mu_0 V_1^{(n)}}$$
. $\tau_2 = \frac{w^2 e^{\frac{c_1 + c_2}{2}}}{\mu_0 V_2^{(n)}}$

and
$$\frac{\tau_1}{\tau_2} = \left(\frac{V_2}{V_1}\right)^n \exp\left[\frac{dv_2}{k}\left(\frac{1}{T_1} - \frac{1}{T_2}\right)\right]$$

This is the same as the empirical result reported by Minford (IEEE Transactions CHMT-5, 297, 1982)

There is a property of the second of the sec

Exposure that discrease with tone is to a degradation, as predicted to the ser-

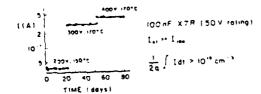


 Dark colors seen in reduced regions hear callinde

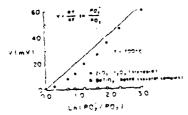
1b. Experimental

Region 1: Background current is electronic, as evidenced by -

• I(I) stable over long time periods

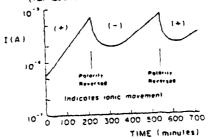


• Galvanic voltages are = zero

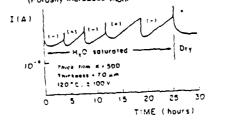


- Negative stable thermoelectric voltages
- Evidence of space charge limited currents

 Exponential increase: polarity reversal effect (1µF Z5U : 150°, ± 100v)



 More rapid degradation for porous thick film, even though 70μm thick. Accelerated by humidity (Porosity increases μ_{ion})

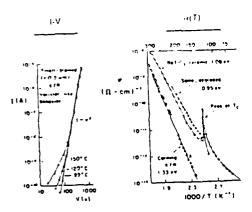


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2 Pussare Effects of Grain Blundaries (GB)

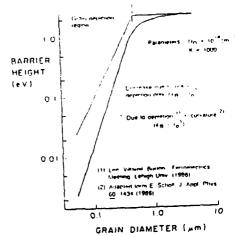
- 28 Surferige of Lift controlled numeral
 - Superchand contents (La V⁰ : 2.5 n = 5.5) resemble valistor in some cases, do not show correct thickness dependence for SCLC.
 - Conductivity discontinuous at Curie temperature



- A superimental ordinario de la completa del completa del completa de la completa del la completa de la completa del la completa de la completa del la co
 - GB barrier rampd in a respired consist process is because of

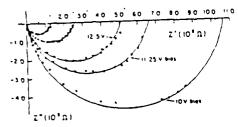
KONONSOLENSONSOLE ESSENSOLE ESSENSOLE ESSENSOLE

- Grain depletion
- ∙ அதன்கள்

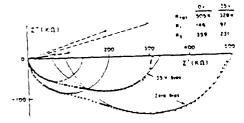


2b. Impedance measurements under bias

Varistor is known GB controlled device.
 (T = 125°; biases 10, 11.25, 12.5, 13.75, 15v)



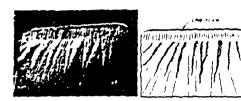
• BaTiO₃ ceramic shows similar reduction. (Polished X7R disc.; t = 0.21mm.; T = 450°C)



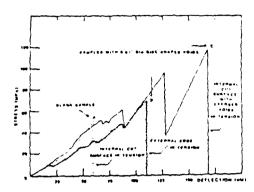
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M14

Line Flaws

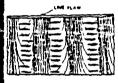


40 MPa, .7 J/m2 void free blank



STRESS VERSUS DEFLECTION OF POLED PZT IN THREE POINT BENOWIG





76 MPa, 4.7 J/m² highly ordered void array

FRACTURE STRENGTHS AND ENERGIES

	BLANKS DISC SHAPED VOIDS 0.010" DIAMETER		
YOUR PLANE SPACING		1,5 mit	2.0 mH
FRACTURE STRENGTHS	68 MPa	DT MPa	117 MPa
FRACTURE ENERGIES	2.6 dem ²	2.7 Jun 2	\$ 7 Jm²

Point





51 MPs, 2.2 J/m² blank has some hackle curvature





70 MPa, 6.3 J/m ² some hackles parallel to and even towards surface under tension

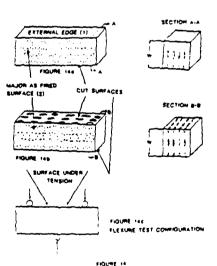


FIGURE 14
CONFIGURATIONS USED FOR 3 POINT FLEXURE TESTS

- (1) surface corrupt male during boung (2) surface corrupt amortade ouring samig





121 MPa, 6.3 J m some disorder in void array

Fast propagation parallel to voids near tensile surface







70 MPa, 6.3 J m². Slaw near void tip, crack curves around void

Flaws

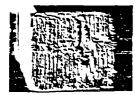




78 MPa, 3.14 J/m² hackles primarily in void free column



117 MPa, 14.5 J/m² origin in between void tips





104 MPa, 6.J/m² sidewise hackles in margin and in void free column





78 MPa, 3.14 Jim² flaw near void tip inside caramic

All samples 0.09" x 0.09" in cross-section

All voids 0.0005" thick





92 MPa, 11.5 J/m² noncritical and critical crack propagation

Note: Upper surface of all samples in tension

OPERATIONALLY INDUCED

THERMAL STREET GRADIENTS

111

MULTILAYER CAPACITORS

JOSEPH P. PONGHERTY

Advanced Materials Technologies

Niles, Michigan 49120

U.S.A.

AUTOHOTIVE APPLICATIONS
INVOLVING AMBIENT TEMPERATURE
CIRCUIT START-UP CONDITIONS
MAY BE A HIGH STRESS MODE
FOR MULTILAYER CAPACITORS
USED IN CERTAIN CIRCUIT DESIGNS

HIGH PERHITTIVITY

FERROELECTRIC MULTILAYER CAPACITORS

HAVE UNIQUE PROPERTIES

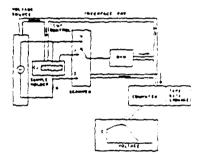
DUE TO POLARIZATION REVEKSAL

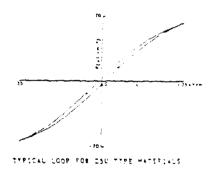
OPERATIONAL FAILURES

A FERROELECTRIC HULTILAYER CAPACITOR HAY
BE UNDER HORE STRESS DURING TYPICAL
CIRCUIT OPERATION THAN DURING AN
ACCELERATED LIFE TEST.

LOW OR ROOM TEMPERATURE START-UP OF A CIRCUIT, WHERE THE CAPACITORS HAVE A.C. OR PULSE DRIVE, MAY BE THE WORST-CASE TEST FOR AM MLC.

A FERROELECTRIC MIC MAY BE MORE LIKELY TO FAIL IN OPERATION THAN DURING A LIFE TEST.





EFFECTIVE DISSIPATION FACTOR

Feff Tid is

"" Frengy lost cycle

" Area of hysteresis loop

"" Frengy stored cycle

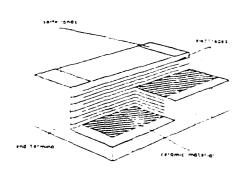
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TYPICAL CHIP CAPACITORS

of at ut to tale

	ACTIVE YOUGHE	SFOSS SISTION
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7 · 9	:: 1	6 -
2.40	1 1	: •
7.55	1 71	3 2*

THE THEAD INTO A PREMIET PREMIETATION

CANDIEST & TOTAL DIE

SEAT REMOVAL PATE + 1.1 #+

WHICH LOWERS THE ACTIVE VOL BY 0.13*G/#ec

TRIP RESTING FATE FOR COLD START CONDITIONS

was loss factors from manufacturers data.

FREQUENCY - 5 %; rms
FREQUENCY - 1 EHE
COMMONTANCE - 2 MIT NE

TYPE	1088 1	TEMP RISE
250	٠.٥	5.26
277	5.7	2.5•

for 1 + 12 v. square wave 18.5 yrms,

ISU -- IB.8*C/sec.

XTF -- 10.2°C/sec.

THERMAL EIPARSION

STRAIN RATE - THERM, EXPANSION COEFF, & HEAT RATE

FOR: HEAT PATE = 23 8TG. sec.

TH. EXP. COEFF. = 6 x 10⁻⁶/°C

STRAIN RATE - 147 : 10-6 - 450.

.....

and a connegnment for neutrope only has a feat offering of about 10^{-2}

Calculated internal stress distribution.

PEAK STRESS LIMITS

MULTILAYER ACTUATOR ANALYSIS (TAKAHASHI): STRAIN = 1840 MICROSTRAIN STRESS = 1000 KG/M²

AN MLC WITH A 120°C GRADIENT FROM
HYSTERETIC HEATING WILL REACH A
PEAK STRESS = 400 KG/M²,
AND HAY ATTAIN THIS LEVEL
IN LESS THAN 10 SECONDS.

S. TAKAHASHI et al.

THE THERMAL EXPANSION DIFFERENCE BETWEEN:

- 1. ELECTRICALLY HEATED BODY
- 2. INACTIVE ENDS

WILL CREATE STRESSES SIMILAR TO THOSE IN PIEZOELECTRIC ACTUATORS.

SINCE THE HEATING MECHANISMS ARE THE DOMINANT DRIVE, THE PEAK STRESSES WILL BE DETERMINED BY:

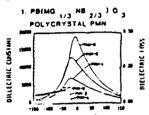
- 1. EQUILIBRIUM TEMPERATURE (about 10-20° above Curie Point)
- 2. THE STARTING TEMPERATURE.

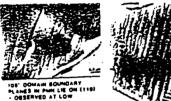
MIC

MATERIALS STUDIED

Dielectric **Behavior**

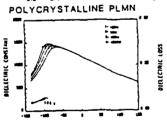
H.M. CHAN, A.I. GORTON, I. CHEN AND





NANOSTRUCTURÉS

M.P. HARMER, MATERIALS RESEAR 2. PB0.9LA0.1 MG0.367 NB0.633 O 3



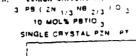


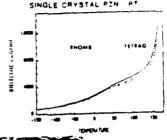


COF 2HAGES OF PO 122 149 1170 2 112 SHOW THE FERROELECTRIC CONAINS UNCER THE DIFFERENT REFLECTIONS

OF RELAXOR FERR

CENTER! LENICH UNIVERSITY, EETHLEHEM PA



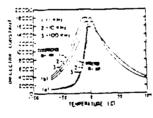


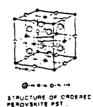




OELECTRICS ACKNOWLEDUMENTS THIS WORK WAS SUP BY NST. OWN AND E'S DE HEMOURS INC.

4. PS (SC 1/2 TA 1/2) 0 3 SINGLE CRYSTAL AND POLYCRYSTAL PST







MICRODOMÁINS 100-500 A IN SINGLE CRYSTAL PST

1-C= 10 3 , O. X. C. X0_0 0 - X0_0

SHORT RANGE CROES

Ordering

Microchemical **Ordering**



POLYCRYSTALLINE PLMN - CDF IMAGE SHOWS ORDERED REGIONS AND APB'S



FERROELSCYPIC DOMAIN
FERROELS TO PMN
LIE ON (100) 170° DOMAINS)
AND (110) (100' DOMAINS)
AND (110) (100' TO CANAINS)
TEMPERATURE ONLY.

SUGSESTED MODE OF ORDERORS IN PMM.



Second Phases

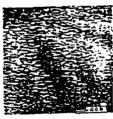




INTERGRANULAR PHASE RICH IN PHOSPHOROUS AND LEAD IN PMN-A



PRECIPITATES IN PMN-B CONTAINING 2 MOL'S EXCESS MGO



CONCLUSIONS

1 AT ADOM TEMPERATURE

1 CAT ROOM TEMPERATURE

1 AT 1-18 C. DOMAINS OBSERVED

1 AT 1-18 C. DOMAINS OBSERVED

1 AT 1-18 C. DOMAINS OBSERVED

1 ALL DOMAIN CONFIGURATIONS ALL DOMAIN COMPIGUANTIONS ONLY THE PROPERTY WITH RHOMBOHEDRAL TRUCTURE OF THE PROPERTY OF THE CEPANICS OF THE PANCH OF THE PANCH

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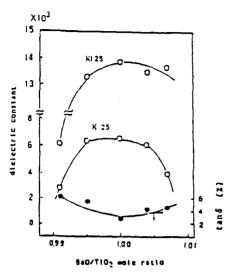


FIG. 1. Effect of BaO/TiO $_2$ more ratio on dielectric properties at 1250°C

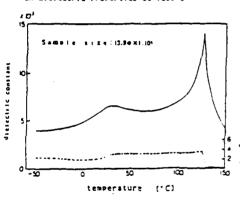


FIG. 2. Temperature desendence of the electric properties of BaTIO₃ ceramic with 820/7/0₃ mole ratio = 1.000



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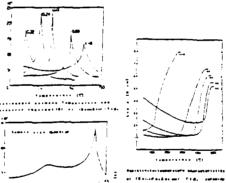
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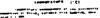
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SEM posto or Bation sawers







LOW TEMPERATURE FIRED GLASS-CERAMIC DIELECTRIC MATERIAL

M TABABATABE & SAWARAMI, M SASABE RESEARCE 1844 DEVELOPMENT DEVELON, ASABE GLASS COMPANY

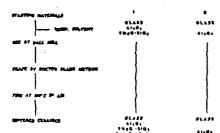
PURPOSE

- 1. Investigate reaction mechanism among borosilicate glass, 2MgO·SiO₂ and Al₂O₃ at high temperature. (below 900°C)
- Features of borosilicate glass-2MgO-5iO2-Al2O3 composite comparing with borosilicate-Al2O3 composite.

RESULTS

- 2MgO-SiO₂ dissolves in the glass, and then B₂O₃ in the glass reacts with Al₂O₃ and 2Al₂O₃ · B₂O₃ crystal phase occurs.
- 2. (1) good sintered
 - (2) chemically stable
 - (3) good mechanical toughness

TERRITORY AL PROCES



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X-ray diffraction patterns of various compositions sintered at 900 C

	GLASS-AI,0,- 2Me0 - 5i0	96% Al ₂ O ₃
former (C)	900	1550~ 1500
f board Strangth (spirm*)	2000	3500
Thermal conductivity (col/dec-un-sec)	0.007	0.05
Thornol Expension Confitting (day")	80×10**	75×10"
Constant (100mm)	6.5	9.0
Designation Factor (1904Hz)	1.5×10 ⁻³	4.0×10**
Pasialisis G-em)	> 10**	1014
Surface Roughness (LIFIE)	0.5	1.0

 Σ

15%

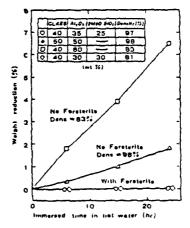
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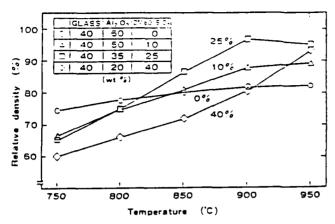
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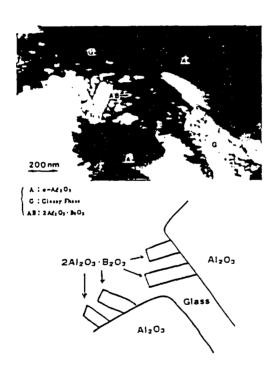
Properties of the substrate



Corrosion resistance to not water at 92°C (semate demonster: 17°7 x 17°7 x 5°7)



Relative density of various glass-Al $_2\text{O}_3$ - 2MgO \cdot SiO $_2$ compositions with temperature.



Transmission Electron Microscope Observation

LOW TEMPERATURE FIRED MULTILATER CERAMIC CAPACITORS WITH N. ELECTRODES.

H.KISH, T.HADA, S.HURAI, H.CHAZOHO and N.YAHAOKA

TRIYO YUDEN CO., LTD.

ABSTRACT: Dielectric materials based on barium titanate and glass components for multilayer ceramic capacitors with nickel electrodes have been developed. The ceramics could be fired at temperatures lass than 1288°C in an atmosphere of low oxygen partial pressure, exhibited high dielectric constants (YSV:18888-12888, X7R)

The multilayer chip capacitors with nickel electrodes using these dielectric materials have good characteristics.

:2700-3300) and high resistivity (above

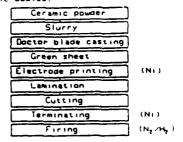
EXPERIMENTAL PROCEDURE

(b) Application to multilayer chip capacitors

Nickel metal powders were used as both of internal and terminal electrodes which were co-fired in the firing process of ceramic bodies.

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Fabrication process of the multilayer chip capacitors with NI electorodes.

RESULTS

(a) Dielectric materials

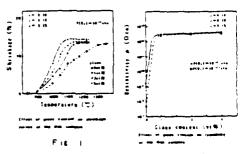


Fig 2

The samples with glass components added are fired with full densification from 1100°C to 1200°C.

Insulation resistance increase markedly on addition of glass components.

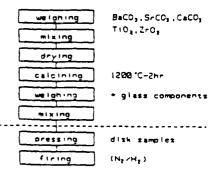
The insulation resistance is higher than $(\theta^{i\delta})$ ohm.cm.

EXPERIMENTAL PROCEDURE

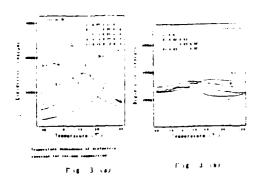
1812 Ohm - Cm) ,

(a) Dielectric materials Composition:

+ Li₂O-SiO₂-MeO glass system (MeO:alkaline earth)

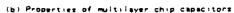


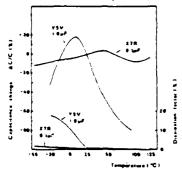
Flow chart of fabrication process of the dielectric materials.



The desired temperature dependence of dielectric constant can be obtained by the use of designed composition as shown in Fig. 3 (a),(b).

specification	dielectric constant
Y5V	10000-12000
X7R	2700-3300

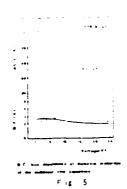


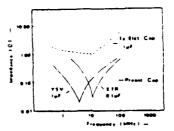


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	8.1			• • •	1 75	111	1.14	1 1 # 10" 100	1 11	-		1

Table 1 Characteristics of the autitiaver this capacitors with Ni ejectrode





Frequency dependence of impodence Fig 6

The characteristics for multilayer chip capacitors with nickel electrodes are shown in Table 1. These capacitors are compactly designed and have large capacitance and satisfy EIR standard specification.

Fig.6 shows the frequency dependence of impedance of the present capacitors in comparison with tantalum electrolytic capacitor.

ESR(equivalent series resistance) is small.

CONCLUSION

- (1) Addition of glass components was found to markedly increase the resistivity when the ceramics were fired in a low oxygen atmosphere.
- (2) The multilayer chip capacitors with Ni electrodes have been developed and exhibited high dielectric constants.

 (150:10003-12000 , X7R:2700-3300)

BARIUM TITANATE CERAMICS FOR BASE METAL MONOLITHIC CERAMIC CAPACITORS

Y. SAKABE, H. TAKAGI and K. WAKINO



Research and Development Department V, Murata Manufacturing Co., Ltd., 2-25-10 Tenjin, Nagaokakyo-shi, Kyoto 617, Japan

1. ABSTRACT

Baraum intensity commics deced with SiO. CaO and ZiO, were fixed under several law except personnels pressures, and their dielectric prodetries were impaired. The delectrics visibled a high dejectric constant (IX-14 DOO) and high resistants (> 10¹¹ O-cm) when they were fixed with an nickel electrics in a reducing similar sensitivity (> 10¹¹ O-cm) when they were fixed with an nickel electrode in a reducing similar sensitivity of 10¹¹ CP(O₂) < 10¹¹ MPs. The dielectrics are similarly for large conditionic monorable correctors with nickel electrodes.

2 EXPERIMENTAL

Two distocraic meterials "A" and "B" were preserved by the conventional powder process, "A" is a new compection and "B" is a normal one.

- A: [(Bar 15Sr2 on Car 10]O] 1 and [(Tis 15 25 10 10 1) + 0.1 at #MnO;
- 8: Bellinge De 1210;

The text taments were precised in dric form (14 mm in diameter by 1,0 mm thick). The drick migh and without Ni-patts on the surface, were sintered under P(Q), I review at 10° to 10° to 10° MPs. An ImGa alloy was applied as a conducting electrode on the sintered disk. Resistance was measured at room temperature on a meganismister at 500 V de or on a resistance most with low voltage. Capacitance were integered on an LF importance positive at 1 V and 1 kHz.

3. AFSULTS

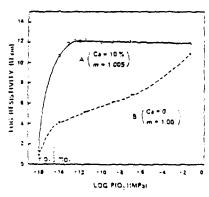


Fig. 1 Resistivity of the "A" and "3" dielectrics sintered under various P(O₂) at 1300°C and 1400°C, respectively, for 2 h.

Figure 2 shows the decembers of the dielectric configure on the singlering abnosthers. The "A" dielectric singlered in the PIO $_2$ 1 rinks of 10" 12 To "10" MPs showed a very high dielectric contrast (14 000) and low distinguish factor (<1.5%). At the PIO $_2$ 1 resions higher than 10" MPs, the dielectric contrast of the Ri-electroped disc degreesed with increasing PIO $_2$ 1.

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The equilibrium P(O₂) for Ni-NiO at 1300°C is 2×10° NPs. But even in the lower P(O₂) resolve to 10° ¹¹ NPs, increase initial on the dielectric teramics was certailly excitated and rected with certainer, resulting in a degradation of the dielectric properties. Firing symposhere for the nicket electrods monolithis coramic capacitors with "A" dielectrics has to be controlled accurately within the P(O₂) ranges of 10° ¹¹ to 10° ¹⁵ NPs.

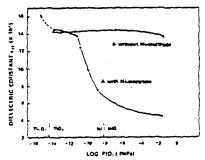


Fig. 2 Dielectric constant of the "A" dielectrics sintered with and without Nielectrode under various P(C₂) atmosphere at 1300°C for 2 h.

The descendance of the diefectric constant on removesture for the " Δ " diefectrics co-fired with the nekel electrods in various $P(Q_{\alpha})$ atmosphere is shown in Fig. 3. The temperature which knows maximum diefectric constant was not affected by the sintering atmosphere.

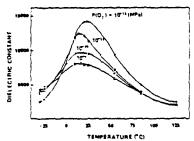


Fig. 3.— Temperature dependence of dielectric constant of the "A" dielectrics sintered with Na electrode under low oxygen partial pressures at 1300°C for 2 h

4. APPLICATION

The resultant material slightly modified from "A" composition was applied to the monolithic capacitor with nickel electrode. The capacitor was made into a large capacitance capacitor from 10 to 100µF for high frequency applications.

Impedance and ESR characteristics of 56u F multilayer capacitor are superior to the 3300u F aluminum electrolytic capacitor at frequencies more than 50 KHz. When 20 amperes of ripple current at 100 KHz are applied to the new capacitor, the surface temperature rise is only 5. C which is one-fifth of that of the aluminum electrolytic capacitor. The results of load life test are shown in Fig. 4, which shows that these base metal monolithic capacitor are as reliable as conventional monolithic capacitors. The failure rate of Z5U-56uF-25 Volt capacitor was estimated to be less than 0.023% per 1000 hrs at rated conditions.

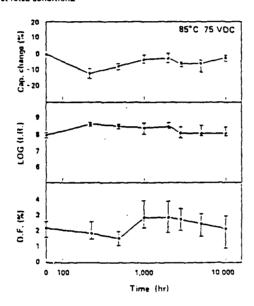


Fig. 4 Load life test results for nickel electrode monolithic capacitors, Z5U 56μF 25 volt. Sample volume was 40 pcs.

		ctrode M Capacito		c		
	ZŠU					
Туре	0.1µF	1.0 _H F	10, F	56µF		
Chip type	•	•	K			
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TEMPERATURE STABLE BARIUM TITAMATE CERAMICS FOR BASE METAL MULTILAYER CAPACITORS

DIELECTRIC MATERIAL

1. SYSTEM;

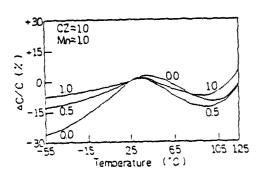
BaTiO3 -CaZrO3-MnO-Y2O3

2. FIRING TEMPERATURE;

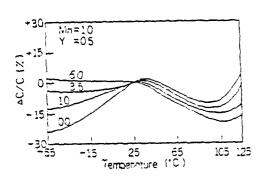
1270-1350°C

3. FIRING ATMOSPHERE;

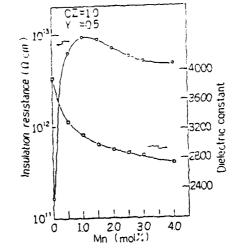
 $PO_2 = 3 \times 10^{-10} - 3 \times 10^{-5} \text{ atm}$.



TEMPERATURE CHARACTERISTICS OF DIELECTRIC CONSTANT FOR VARIOUS Y, C, CONTENT(MOLE)



TEMPERATURE CHARACTERISTICS OF DIELECTRIC CONSTANT FOR MARIOUS CAZEO, CONTENTINOLE,



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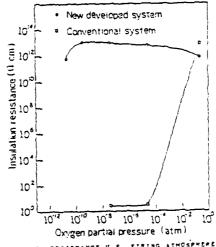
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INSULATION RESISTANCE AND DIELECTRIC CORSTANT V.S. MNO CONTENT(MOL%)



INSULATION RESISTANCE V.S. FIRING ATMOSPHERE FOR CONVENTIONAL SYSTEM AND NEW DEVELOPED SYSTEM

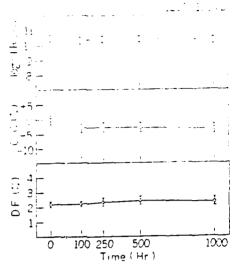
APPLICATION TO MLC WITH NICKEL ELECTRODES

CHIP SIDE	7 2 3 1 1 5 5
GREEN THIUMARDS	≥5 <u>μ</u> μπ
NUMBER OF LAYERS	20 OR 40
FRECTOUDES	NICHEL

HLC CHIP CONSTRUCTION

CHARACTERISTICS	ZOLAYERS	AULAYERS
CAPACITANCE (NF)	53 4	110 5
DF (%)	2 2	2 0
iR (GΩ)	2.5	1 2
CR PRODUCT (AF)	1300	1300
BDV (VDC min.)	500	400
TCC (EIA)	X 7 R	X7R

ELECTRICAL CHARACTERISTICS OF MLC WITH WEN DEVELOPED DIELECTRICS AND NICKEL ELECTRODES.



LIFE TEST AT 1.25°C, 100VDC

BARIUM MODIFIED LEAD ZING NIOBATE DIELECTFICS FOR MULTILAYER CERAMIC CAPACITOR

E. INAGAEI, Y. YAMASHITA and E. YUUEI

Engineering Department, Marcon Electronics Co., Ltd., 1-1 Saiwai-cho, Nagai, Yamagata 993, Japan

METRACT

Substitution effects for lead sinc niebate based evranic by barium and titanium have been systematically investigated. It was found that the partially substituted lead sinc niebate divisorities by barium and titanium has shown to be a promising candidate for swittinger coronic capacitor. This curumic meterials can be fired at 180 - 1.130°C, and exhibit high dislectric constant of 4,000 - 6.500, and high insulation resistance of 1910 - 4910 - 3500, and high insulation resistance of 1910 - 4910 - 3500.

In this system, a (Pb_{0.13}ba_{0.27})/(14m_{1/2}/m_{2/3})_{0.50}Ti_{0.40}Do₃ shows dislectric constant of 8.448, dissipation factor of 1.91, insulation resistance (Cr. product) of 14,500 at 125°C, respectively. This material offers sweetier performances and low cost to conventional barium titanate based coranie.

177700227108

In order to improve disadventures of barjum titanote based disluttric material, studies of new high dislettric constant relaxor materials are widely carried out. The authors have succeeded in easily synthesizing perovshite type lead line nimmate as a ceremic form. By means of bertial substitution by struntium and titanium. In the present study, dislettric properties of the lead line minomate based compositions, in which the dislettric constant maxima show around the room temperature, has been investigated by the adjustment of the amount of berium and titanium substitution.

Samele Presention

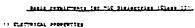
- Competition
- (Pb₁₋₁8e₁-)[[Zn_{1/3}-Nb_{2/3}]₇-Yr₁-10₃ - ++0=0-3-y+06=+0
- Rew Materials
- Pb0, 8eCO₃ , ZnO₄ , Nb₂O₃ , TrO₇

- * Calcining 750°C × 2H
- Sintering 980 ~ I, 150°C ± ZH
- · Specimen Size 12 · 10 mm
- Meesurement

X-ray, Relative Permethiolty, Dissipation Factor, Electrical Resistanty Curie Temperature, Capacitance Temperature Change.

COMCLUSION

Dislectric Properties of (Pb., Be_1ffin_{1/2}Mb_{2/2}', Ti, 10') rerance, were investigated from a viewpoint of septication to multilayer expect capacity (MLC). The cereast materials can be fixed 980 - 1.130°C and emibbt high dislectric constant of 4,000 -8.30C. Effects of 8e substitution for Pb is summarised as follows: stabilises perovskite structure. Improves sinterability, improves mechanical strength, increases slectrical resistivity, increases breardown voltage, shifts Curib temperature and increase sintering



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* Eigh disiostric cometant	2+1.020
* Souil Temperature goulficient of gamestones	8/7-2.5.11

* Low dissipation (actor * Sigh brookdown valtage * Small de Bise dependuncy

8.7.8.1050/cm 8.4.705 of 150/cm

21 PRISICAL PROFESTIES

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* Figh mortherical strongth B.S.:stage
* Com mated absorption U.A.:0.19

THE PROPERTIES

* Brood sintering (separature

. Comp stateLage combustaries

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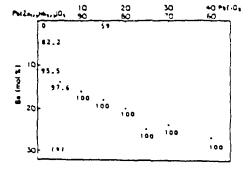


Fig. 1. Relative amount of perovskite phase for the PBIT system.

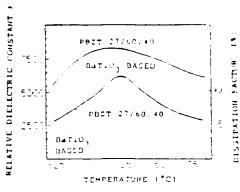
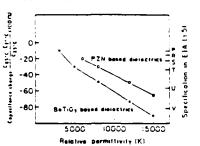
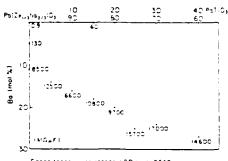


Fig. 2. Dielectric properties for the PBIT 27/50/40 and conventional YST characteristics BaTiO₃ based dielectric.



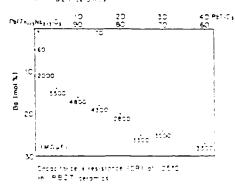
Temperature capacitance change vs. relative permittivity of PZN based MLC and BoTiO₃ based MLC.

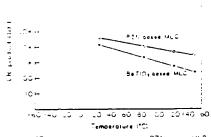


Capatitance a resistance (QR: a) 25°C in PBZT ceramics

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CR product vs. temperature of PZN based MLC and 3sT.03 based MLC.

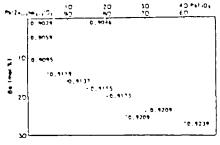


Fig. 3. Tolerance factor for the PBIT system.

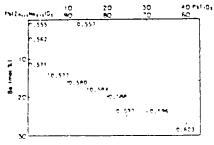
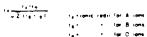


Fig. 4. Impunt of ionic character for the PBIT system.

[BASIC REQUIREMENTS FOR PEPOVSKITE STRUCTURE!

13 Tolerance Factor (1)



21 Ionic Character

$P_{kg} \leftarrow \exp(\frac{1}{2}\left(X_{g}\right)^{2})$ $= P_{kg} - \text{amount of lanks character}$ $= x_{g} - \text{asscripting getting value for } A \text{ son}$

Effects of Balsubstitution in PIN

* Signification perovasite structure

- 2 mproves mechanica strength
- _
- T. maraves sinteresimit
- A: Saille Surie lemperature
- " Acresses fring temperatur

DIELECTRIC RELAXATION STUDIES IN SOME POLYMER - PIT COMPOSITES

A. M. VARAPRASAD

Department of Physics, Sophia University, Kioi-cho, Chiyode-ku, Tokyo 102, Japan

The in the repid increase in application of interplactics in distribute industry. Entingential filance and nodes described how ther experience extensively 17.21 and represents materials once on of such interplactic materials once on the interplactic materials in the interplactic positions of interest in a polymer applicable once only a state of a contract of the interplactic decision of extensial termelolatities doe to the oral presentation. Notice experiently of extensial termelolatities have and frameworks one monitor fine to the properties have been motived (13 to composite, heaterly displactic relaxation obtains and the molecular materials of the molecular materials and the molecular materials and contain one-function opening and properties according to make the composite of the original mortal contains one-function.

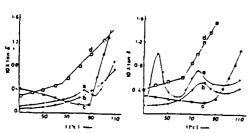
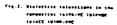
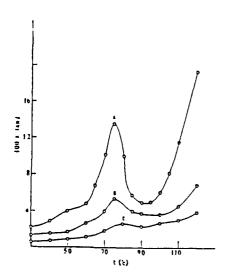
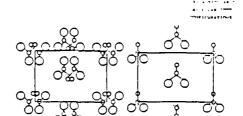


Fig.1. Distortic relaxations in some polymers used for compacite formation talva-VC lelouge telact (d)M0.PVC





Temperature vs. tan\$ for PDT_PVDF COMPOSITES (a) 100Hz (b) 1KHz (c) 10FHz.



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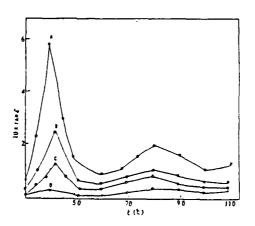
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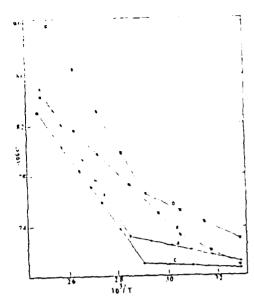
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In the doce of PVBT, a retaining around 10 C was some to grow due to the immediate motion in the TUTC confideration. To such retainetion we become them for the six trees (TVTC) confideration, to rest the six trees (TVTC) confideration, to rest the secondaries, the six trees of the six trees around this temperature. The observation of mor retaining more in the pumpication of the TVTC of the TUTC confideration, six the state of the trees of the major of the major of the trees of the

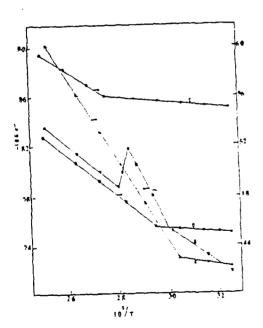


Temperature vs. tan\$ for PIT-VAVC Composites (a) 100Hz (b) 500Hz (c) 1KHz (d) 10KHz.

IN VA-VC COMPOSITE THE OBSERVED NEW RELA-MATION AT 40 C VAS ATTFIBUTED TO THE SEG-MENTAL HOTION OF VA AND VC SEGMENTS. In the case of pure VA-VC the relaxation occurs at -20 C. Owing to the coupling of polymer segments with the polarisation charge of PIT particles the relaxation has been shifted to higher temperatures.



Electrical conductivity Vs. temperature inverse for different polymers.
(ANVA-VC IDIPVDE ICIEFOXY (UNIR-PVC



Electrical conductivity Vs. temenerature inverse for different composites.
(AIVA-VC (BIFVOF (CIEPOXY (DIRF-PVC

THE PERSON OF TH

13.4 0	7 7 7	4/			
	15	₩**** <u>,</u>	121.*	- :	
. A /C	1.23	1, 11	.:		
PVTF	:	1.49	* * *		
EPOXY	1.14	3.11	٠. ،		
48 JPVC	6.22		. •	:	

 Δ E below and above diasa transition temperature t_{g}

- 1. Selpwitti, &E lacresses on ideodrice infraction due to the jectesse in tree volume svaluable for electrical conduction.
- Electrics, university, a noticed for IPCAY and MR-PVC composition where there are no new distance true relaxations on composite formation.
- 1. We dielectric felamations in WA-VC and PVOF comcosites increase the AF as the traced inares cets released due to the Wolecular motion of the polymer chains.

MICROWAVE DIDLECTRIC PROPERTIES OF Pb (%r, Ce)O3 CERAMICS

K. MURANO, K. TATSUKI

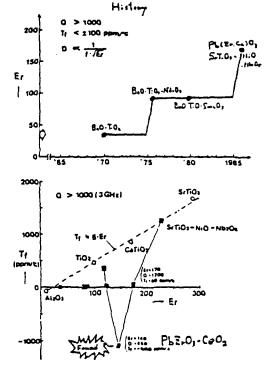
Sony Development Center, Sony Corp. Toxyo, Japan S.MISHIGAKI, S.YANO, H.KATO Marumi Technical Lab. Narumi China Corp. Nagoya, Japan

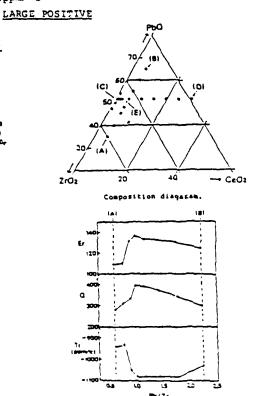
CERAMICS USED AT MICROWAVE FREQUENCIES

- (1) A HIGH DIELECTRIC CONSTANT (E,)
- (2) A HIGH Q FACTOR (Q)
- (3) A NEARLY ZERO TEMPERATURE COEFFICIENT (T_f)

E_r>100 Q>1000 T_f>100ppm/⁰C

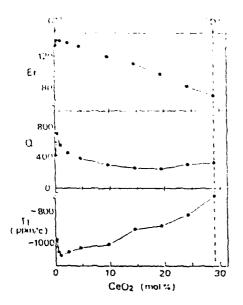
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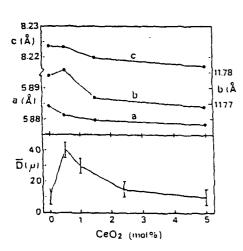


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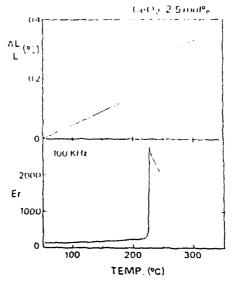
Dielectric properties
as a function of
Pb/Tr ratio at 3GHz.



Dielectric properties of Pb2r03 vs CeO2 content at 3GHz

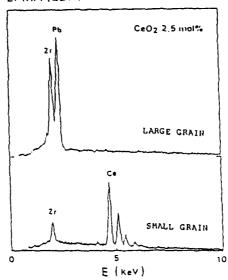


The change of lattice constants and grain size vs. temperature.



The thermal expansion and $\boldsymbol{E}_{\boldsymbol{r}}$ vs. temperature.

EPMA (EDX)



The compositions of grains.

Dielectric properties of commised ceramics

Comp.	(1) PoZrO3-C#O2	(2) SrTIO3-NIO -Nb2O5	(1)+(2)
Er	140	230	170
, a	850	7300	1200
Tr (ppm re)	-108G	1250	80

HIGH DIELCTRIC CONSTANT CERAMICS FOR MICROWAVE RESONATORS

H. SATO, K. AYUSAWA, M. SAITO, and K. KAWAMURA

Research Laboratory, Oki Electric Industry Co., Ltd. Tokyo, Japan.

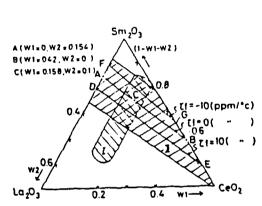


Fig.) The relations of rare earth oxides in the (BaO){ $(Sm_2O_3)_{i-w_1-w_2}(CeO_2)_{w_1}(La_2O_3)_{w_2}$ } (TiO₂)₄ system.

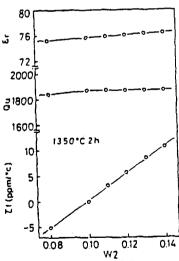
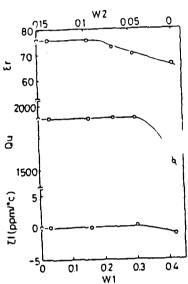


Fig.2 Dielectric characteristics of the system (5a0){(5m₂0₃)₀₈₄₂-w₂(CeO₂)₀₁₅₈(La₂O₃)_{w2}} (TIO₂)₄ as a function of W2.



=

Fig.3 Dielectric characteristics of the system $(Ba0)\{(Sm_2O_3)_{1-W1-W2}(CeO_2)_{W1} (La_2O_3)_{W2}\}(TiO_2)_4$ as functions of W1 and W2

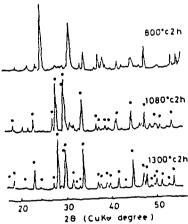


Fig 4 X-ray diffraction patterns of (BaO){(Sm₂O₂O₂O₂(CeO₂)₀₁₅₈(La₂O₃)₀₀₀₀}x(TiO₂), system ceramics after freat treatment x=010 •:BaTi₄O₄ • Ba(RE)₂Ti₅O₁₄ RE = Sm,Ce,La

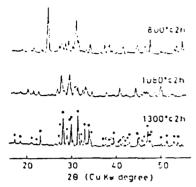


Fig 5 X-ray diffraction patterns of $(BaO)\{(Sm_2O_2)_{O_2O_2}(CeO_2)_{O_2O_2}(La_2O_2)_{O_2O_2}\} \times (TiO_2)_{A}$ System ceramics after heat treatment A=0.50 • $Ba(RE)_2I_1O_2O_4$ • BaI_1O_2

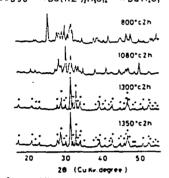


Fig6 X-ray diffraction patterns at (BaO)((5m₀O₂b₂)₂(CeO₂b₂)₂(C₁O₂b₂b₂)₂(TiO₂b₂ system ceramics after heat freatment.x=10 +:Ba(RE.)FigO_{2c}RE=Sm₁Ce₂La

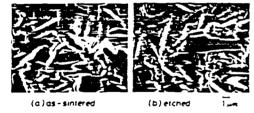


Fig.7 SEM photographs as-sintered and etched (BaO) $\{(Sm_2O_3)_{obs}(La_1O_3)_{obs}\}(TiO_1),$ arramics in

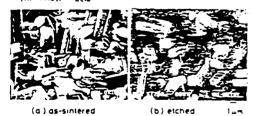




Fig.9 SEM photographs as-sintered and etched $(6a0)[(Sm_2O_3)_{0.80}(CeO_2)_{0.20}(TiO_2)]$, ceramics in LHF+HNO,) acid

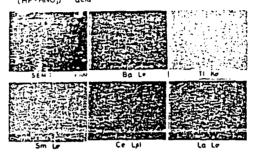


Fig 10 X-ray images of BaO+Sm₂O₂CeO₂·La₂O₂·TiO₂ ceramics.



Fig 11 X-ray Images of BaO-Sm₂O₂CeO₂TiO₂ ceramics

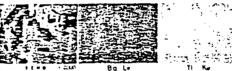


Fig 12 X-ray images of BaO-Sm₂O₃-CeO₂TiO₂ ceramics

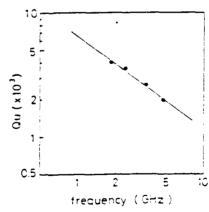


Fig.13 Qu values vs frequency for BaO-Sm₂O₃-CeO₂-La₂O₃-TiO₂

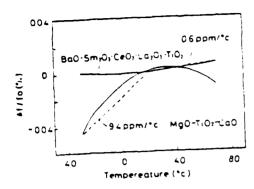


Fig.14 Resonant frequency vs temperature

Table 1 Properties of Ba0-SmyO₃ 2eO₃ LaiO₃ TiO₃ ceramics.

Dielectric constant Er 755 1870 lat 5 GHz Unloaded G. Qu (6300 lat 1 5Hz)

Temperature coefficient If 0 ppm/*c

Metalization by chemical Very easy
plating (susceptible to
HF+HNO; mixed
acid)

.

-

HIGH-Q DIELECTRIC RESONATOR MATERIAL FOR HILLIMETER-NAVE PREQUENCIES

H. TAMURA, D. A. SAGALA, M. MURATA, and K. WAKINO Research & Development Department V. Murata Manufacturing Co., Ltd., Kyoto, Japan

INTRODUCTION AND RESULT

Dielectric resonator deramics have gained an important position as a key element for microwave components. Among many materials developed for dielectric resonators, those with complex perovskite structure have very high Q values. Complex perovskite materials of the system Ba(Mg,Ta)O3-BaSnO3 are investigated here. This system presented a very high Q value and would be useful for applications of millimeter-wave frequency.

The addition of ${\tt BaSnO_3}$ on ${\tt Ba(Mg,Ta)O_3}$ was effective both to obtain a 0 ppm/°C temperature coefficient of resonant frequency and to improve a Q value. Although ${\tt Ba(Mg_{1/3}Ta_{2/3})O_3}$ had a perovskits pseudocell and hexagonal superstructure, the superstructure was not formed after the addition of ${\tt BaSnC_3}$ of more than about 10 mol\$. Sintering of solid solution ${\tt Ba(Sn_{0.1}Mg_{0.3}Ta_{0.6})O_3}$ was accelerated compared to those of ${\tt Ba(Mg,Ta)O_3}$ alone, and the microwave Q value was also improved.

The resultant dielectric characteristics are as follows: K=24.5, Q>20,000 at 10 GHz, and temperature coefficient of resonant frequency, Tf=0 ppm/*C.

In a study investigating the crystal structure of the complex perovskite material, Galasso and Pyle reported that complex perovskites containing Ta ions had pseudocubic unit cells with hexagonal superstructures because the two B-site ions were of ordered configuration.

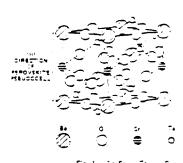
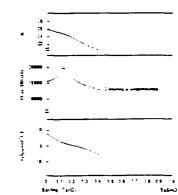


Fig. 1. +6asSr_{3,23}Ta_{h 67} (O₂).

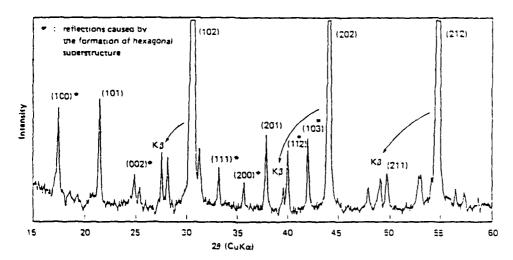
Tig. III. F. Galasso and J. Pile "Torcering in Campounds or the AIBF_{3,23} Ta_{h 67} (O₂ Type 1) inorcanic Chemistry, 0.3 ± 482 (1963).



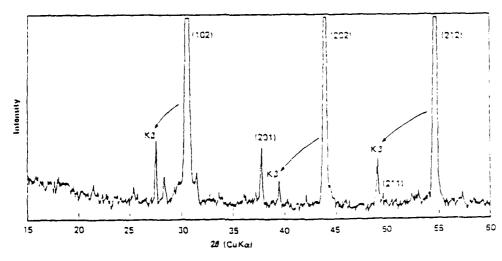
Dielectric characteristics of Bat Maj TavCv = BaShOv ceramics

 ${\sf Ba(Mg_{1/3}Ta_{2/3})0_3}$ has pseudocubic unit cells with hexagonal superstructures. Fig. 4 shows the X-ray powder diffraction patterns of this material. The Miller indices parameters in the figures are those of hexagonal superstructure, and the peaks marked by an asterisk are caused by the formation of superstructures.

The peaks of superstructure have disappeared in the X-ray diffraction patterns of $Ba(Sn_{0.1}Mg_{0.3}Ta_{0.6})O_3$.



X-ray powder diffraction pattern of Ba(Mg 1/3 Ta 2/2)O₃.



 F_{1g} $\stackrel{1}{\leftrightarrow}$. X-ray powder diffraction pattern of Ba(Sno.1 Mg o.3 Ta o.6)O $_3$

Fig. 5 shows the frequency dependence of this Balish, Mg, Ta, Γ_0 ceramic whose Tf is optimized to 3 ppm $^{\circ}$ C.

Dielectric characteristics at microwave frequency can be determined mainly to the ionic polarization which is strongly related to lattice vibrations at far infrared region. The dielectric constant given here is constant in the microwave region, and the dielectric loss increases proportionally to frequency.

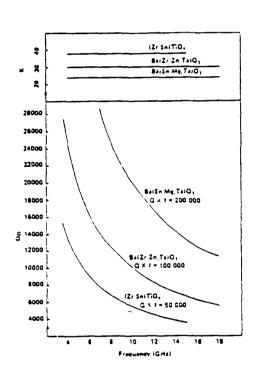
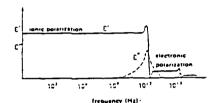


Fig. 5 Frequency vs. K and Q for Ba(Sn. Mg, Ta)O3 ceramic



$$\dot{\varepsilon}(\omega) - \varepsilon(=) = \frac{\omega_{\tau^{-1}} \cdot (\varepsilon(0) - \varepsilon(=))}{\omega_{\tau^{-1}} \cdot \omega_{\tau^{-1}}(\tau(0) - \varepsilon(=))}$$

under the condition of $\omega^{\sharp} \ll \omega_{\mp}^{-1}$,

$$(-1)^3 - (0)^3 = (-1)^3 - (-1)^3$$

$$tan\delta = \frac{\mathcal{E}(\omega)}{\mathcal{E}(\omega)} = \frac{\gamma}{\omega \gamma^2} + \omega$$

निष्ठ है Dielectric Characteristics at microwave frequency

$$E''(\omega) = 2n\kappa = \frac{4\pi\rho_1 + \omega_1^2 + (\gamma_1\omega)}{(\omega_1^2 + \omega^2)^2 + (\gamma_1\omega)^2}$$

where, $4\pi\rho_{\parallel}$; Strength

7 : Width

பு : Resonant frequency

n : Refractive index

x : Extinction coefficient

R : Reflectivity

Far infrared reflection spectra were taken in order to get the information of lattice vibrations.

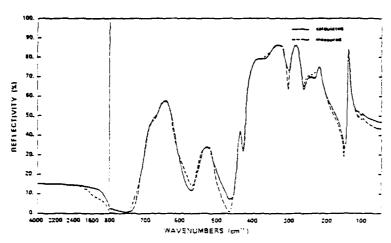
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Fig. 7 shows the measured and calculated reflection spectra of Ba,Mg,Ta O_3 ceramics. The crystal structure of this material belongs to the space group Did of a trigonal system. Taking \overline{O} point or K=0 into consider, whose point group is Did, lattice vibrations can be written in terms of normal modes such as 4Alg+A2g+5Eg+2Alu+8A2u+10Eu.

Among them, A2u and Eu modes are infrared active. And as one of the A2u and one of the Eu modes correspond to the uniform displacements of ions, the number of infrared-active modes to be observed is 16 at most.

The dispersion parameters used for analysising the reflection spectra are also shown in Fig. 7. Table 1 shows the measured and calculated dielectric characteristics at 10 GHz. They show preferable agreement.



 F_{15} ? Measured and calculated far infrared reflectivity of BaiMg % Ta % O₃ decamic

ı	w ı	#1/w1	اب/ا-	440
1	104 0	0.000	0.030	0.14
2	115.0	0.000	0.030	0.10
3	140.0	0.006	0.018	3.70
4	150.0	9.000	C.C.T.	0.20
5	222.0	0.000	0.045	4 23
	240.0	0.065	0.020	6.30
7	276.0	0. DOG	0 046	3.80
	212.0	0 000	0.080	1 50
•	368.0	0.000	0.120	0.25
10	434 0	0.006	0.025	0.03
11	574.0	0.000	0.090	0.60
12	675 0	0.000	0.045	0.57
13	\$70.Q	0.000	0.065	0.04
				5.20

Table I Measured and calculated dielectric characteristics for Ba(Mg ½Ta ½)O₂ ceramic at 10 GHz.

	ε	Olat 10 GHz)	r,(ppm/*C)
Measured	24.8	16000	80
Calculated	26.7	24900	

$$\frac{1}{Q} = \tan \delta \frac{\sum 4\pi \rho_1}{E_2 + \sum 4\pi \rho_1}$$

\$ NISPICALL \$ YANO, H. KATO and T. NONOMURA

Naturni Technical Laboratory, Naturni Chian Corporation, Nagova, Japan

ABSTRACT. Microwave Properties of BuO-TiO₂-WO₃ ceramic system were investigated. Audition of a small amount of WO₃ to BuO xTiO₂ leads to an explicit improvement of O and Ti (temperature exciticient of resonant frequency). Microwave properties of the compositions with x = 4 to 4.5 and y = 0 to 0.00 in the equation of BuO-xTiO₂-(1+x)yWO₃ were observed. With the range of x = 4 to 4.3 and y = 0.02 to 0.00 to 0.00 higher O values (NEEL-9REI) at hGHz) and lower Tr values of nearly zero (-0.5 to 2.5 ppm/C) with E of 35 - 36 were obtained. These ceramics had three kinds of crystallines composed of BuTi₂O₃, Bu₂TuO₃, and BuWO₄. It was found that these improvements seem to be attributed to BuWO₄ crystallines with a negative Ti, which is segregated as a secondary phase by WO₃ addition in the dielectries.

I. INTRODUCTION

Ceramies of the TiO₂ rich region of BuO-TiO₂ system such as BuTi₂O₃.¹¹ and Bu₂TuO₃.²¹⁻¹¹ are well known to be good dielectric resonator materials at microwave frequency. In order to improve the O values, such methods as chemical treatment⁴⁻¹⁰ of calcined materials or addition of small amounts of Mn⁷¹ were reported previously. There are, however, few data on the reduction of Tr. The optimum of these published data for BuO-TiO₂ dielectrics are understood as following: BuTi₂O₃ (BuO-4TiO₂): E=3X, O=400 at 4GHz, O=600 at 6GHz), O=600, O=600 at O=600.

In our case, the segregated BaWO, crystallines formed by WO, addition have an advantage for both improvement of O and Tr. This paper is mainly concerned with the relation between the WO, amount, the microstructure and the microwave properties.

2. EXPERIMENTAL

2.1. Material and Procedure

The starting materials commissed of BuCOs. TiO₂, WOs and MnCOs powder with a purity of W17 to W1974 were mixed to be the designated composition mentioned above, in which MnO was fixed to 0.1 mol/4. The mixed powder was coloned at 1188FC in air for 4Hrs. Bull milled powder was cold pressed into disks and then sintered at a temperature ranging between 13MFC to 142FC in O₂ for 2Hrs.

2.2. Measurement

The microwave properties of the dielectrics were measured by the reconant cavity method on the TE_{HA} mode at 6GHz XRD, SEM and EPMA analysis were used to examine the microstructure of the dielectrics.

3 RESULT AND DISCUSSION

In order to study microwave properties for our dielectrics, we selected several points of $x(4 \sim 4.5)$ in the composition written as $BaO(xTiO_{2}(1 + x)vWO_{3})$.

The properties of BuO-4TiO₂ and BuO-4.5TiO₂ with a small amount of WO₃ (y=0=0.0144) were represented typically in Fig. 1. In each case, the addition of WO₃ at $y=\frac{0.0000}{0.0000}$ shows a remarkable increase of O (711X), S7(X)=RXXI)=RXXI)—RXXII), which is however saturated with further addition. It is still difficult to explain this favorable O 0.0000 0.0000 (at $y=\frac{0.0000}{0.0000}$)

On the other hand, it is well explained from Fig. 1 and the microstructure of these dielectrics (Fig. 2) that the change of £ and Tr seems to depend on the segregation of BaWO, and BaTaO₂, in BaO-4.7TO₂ or of BaWO, and TrO₂ in BaO-4.7TO₂. The increase of £ and Tr is due to segregation of TrO₂. The decrease of £ and Tr is due to segregation of BaWO₄. It is thought from the optimum data of Tr. -0.5 ppm.**C for BaO-4TrO₂:0.1WO₃ (y=0.02) that BaWO₄ must have negative Tr with smaller £ than Bi₂Ti₂O₂, and BaTi₃O₄. The segregation of Ba₂Ti₂O₃, is effective for £ increase and Tr decrease. Therefore in order to obtain a dielectric resonator with high O and zero Tr with relatively high £, coexistence of three £inds of crystallines of BaTi₃O₄. Ba₂Ti₂O₃, and BaWO₄ is required. (£=35-36). The reaction equations with WO₃, which was identified by EPMA quantitative analysis for the microstructures, would be interpreted as follows. Table 1 is the summary of our study.

- (1) Bao4TiO4BaTi,O4 WOI BaTi,O4 + BaiTi,O4 BaWO4 BaOTi,O4 + BaiTi,O4 - BaWO4 + WOI - BaiTi,O4 - BaiVO4 - TiO5
- (2) BaO4 5TiOy(BaTinOxy + WOx BaxTinOxy + BaWOx + TiO)

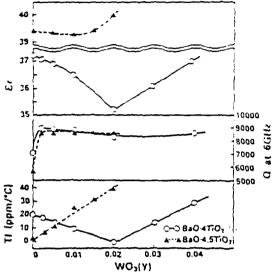
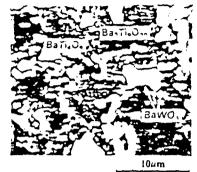


Fig. 1 Dielectric Properties of ItaO:4TiO₂:(1+4)yWO₃ and BaO:4.5TiO₂:(1+4.5)yWO₃ at 6GHz

Table 1 Dielectric Properties of BaO-xTiO2 (1+x)yWO3

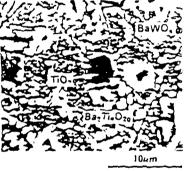
Comp	osition	Prope	erties at	6GHz	95-
×	У	3	a	₹1	Phase
4.0	-	37	7100	19	BT.
4.0	0.02	25	8400	-0.5	8T4, 3T4 5, 2W
4.2	0.01	37	0085	1.6	8T4.8T45.3W
4.3	0.005	38	8300	2.5	BT. ST. S. SW
4.5	- j	29	5700	1.4	BTas
4.5	0.002	39	8800	4.0	BT. s, BW.T
			` _		2 200

BT. BaTiaOg, BT. 9. BazTigOzo, T.TiOz, BW: BaWO.



1868 1868 5580

 $8a0.4TiO_2.0.1WO_3 (y = 0.02)$



 $BaO-4.577O_2 \cdot 0.01WO_3 \text{ (y = 0.002)}$

Fig. 2 Microstructure of BaO-4TiOy-0.1WC, and BaO-4.5TiOy-0.1WO,

REFERENCES

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- H.M. O'Bryan and J. Thomson, Jr. 14 New Biol-Tiol Compound with Temperature-Stable High Permittivity and Line Microwave Line. Jour. Am. Ceram. Soc., 57 (10) 450-453 (1974).
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- H.M. O'Brvan and J. Thumson, "BayTinOn with Improved Microwave Lins Quality" Am. Ceram. Soc. Annual Meeting, 121-E-Nh, May 1 (1986).
- 7. S. Nomura, K. Tomava and K. Kaneta, "Effect of Mn Dopine on the Dielectric Properties of BasTiaOsa Ceramics at Microwave Frequency", Jup. Jour. Appl. Phys. ## (7) (125-1128 (1983).

Summary

- : النور (1 (4000 4000 ما 16017) was attained by ending a small amount o الالاي ناور (1 (1 مال) المال) المال (1 (1 (1 مال) المال) المال) المال (1 (1 مال) المال) المال) المال) المال) المال
- Enterprise to the same the author a small amount of WU, 10 is not to Batti 4101, (tall,), resulting in ternary phases containing BaT..Us. BayligUp and BaWU,
- 3: Excellent deflecting resonator (C = 35, Q = P400 at 6GHz, Tj = 0) was obtained by a composition of BaU 4TiO₁ 0 1WO₂
- (i) It was found that SaWO, compound has negative (i.

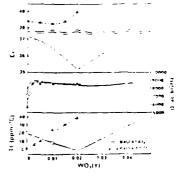
Microstructure of BaO-4TiO₂-0.1WO₃ and BaO-4.5TiO₂-0.01WO₃





41.0; 13 + 410 02WO, BaO 4 STIO; (1 +

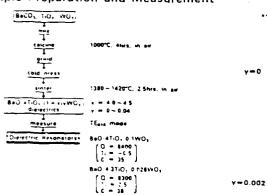
Dienostric Properties of Bacc 47-0 - 1 = 40.000 and BaO 4 STIO₂ (1 = 4 00000) at 6GHz

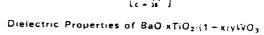


DIELECTRIC PROPERTIES OF BaO-TiO₂-WO₃ SYSTEM AT MICROWAVE FREQUENCY

Microstructure of BaO-xTrO₂(1 = F)vWO₃ (x=4~4.5) | r=0~0.04) Cerainings by SEM and EPMA

Sample Preparation and Measurement

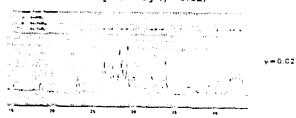


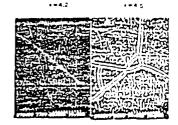


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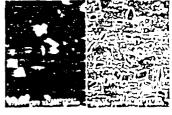
Bt. Bat .Gu Bt., Bestudie * TiOs Ber Bawo.

X-ray Diffraction Pattern of BaO-4TiO $_2$ -0.1WO $_3$ (y=0.02)





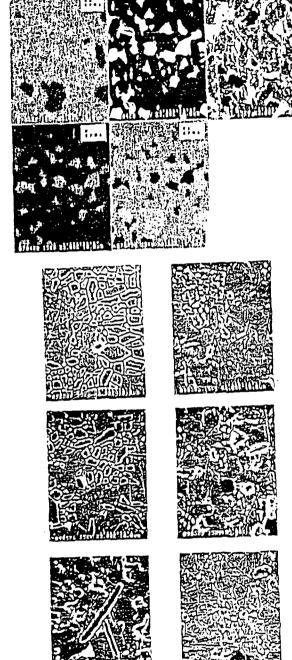








y = 0.04





FERROELECTRIC AND PYROELECTRIC PROPERTIES

OF SPUTTER-DEPOSITED FOR AND PT FILMS

H. ADACHI, T. SHIOSARI, and A. EAWARAIA

Department of Electronics, Faculty

of Engineering, Kyoto University,

Sakyoku, Kyoto 606, Japan

ABSTRACT: [111]-oriented PZT(90/10) films have been successfully grown with good epitaxy onto the c plane of sapphire and epitaxial Pt film substrates by the rfmagnetron sputtering method. The crystallographic identifications of these PZT and PT $\,$ films are made by the X-ray and PHEED measurements. Dielectric, ferroelectric and pyroelectric properties of the films are measured. Pyroelectric coefficients at room temperature have been determined as 4.5 and $3.5 \times 10^{-8} \text{C/cm}^2 \text{K}$ for epitaxial FZT and polycrystalline PT films, respectively. Epitexial PZT(90/10) films on Pt/sapphire possess desirable properties for potential applications in pyroelectric devices.

Table 1. Sputtering condition

Targets	PST: A mixture of Pb(Srg aTime.)C.
	powder with excess PBO dff1004ts PbT10;: PbT10; deramids with excess PbO df 10 - 15wt%
Target-substrate distance	39 - 44mm
Input power	around 100W
Sputtering gas pressure	2 x 10 ¹³ Torr
Sputtering gas conten	Ar(803) - 0 ₂ (208)
Substrate temperature	580 - 680 to

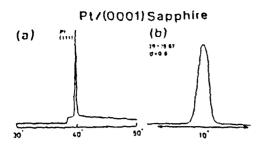
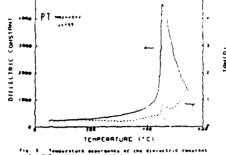


Fig. 1 Tray difference partners of a fintimum they thin film on the c plane of capphire.



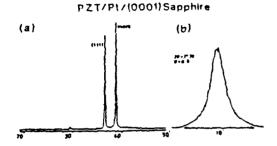
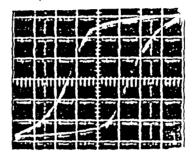


fig. 2. Every diffraction pottures of a Pry(90/18) film on the objection Ps/Dapphire substrate.



q. 6. D-C hysteresis loop Of a PIT film with a thickness of live. P. in lbw/cm and E. in Jav/cm. Scale mithi x axis: 25kV/cm/div., y axis: 15wC/cm /div..

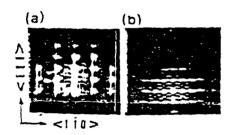


Fig. 3. RHEED patterns of epitaxial Pt (a) and PIT'90/10) (b) films on Pt/sappnire.

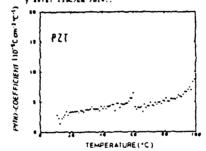


fig. 7. Tumpetisty dependence of the prescineral emofficies of an ex-grown fly file without poline transmist.

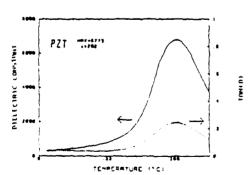


Fig. 4 - Temperature dependency of the dislectric constant of a P27/90/10/ film on the Pt/emponers.

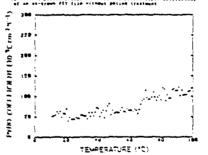


Fig. 5. Temperature dependence to the primerettic checkpoint of a FST flux with powers treatment.

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PYROPLECTRUC AND ELECTRICAL PROPERTIES OF HODDIFFED LEAD ITTARATE CERAMICS

N. TOMPROSE

School of Science and Engineering, Vascda University, Tokyo, Japan

ABSTRACT:

Pyroelectric and electrical properties of the modified (Pb. Ne) ((Co, /, ti,/,), lilly ceramics (He=Ba Sr or Ca) containing small amounts of HnO and NiO have been investigated. These ceramics are characterized by highapparent density, small dielectric constant (about 200) and facility in poling procedure. Among the ceramics substituted with the alkaline earth metals, the Co-modified ceramics show markedly excellent pyroclectric and piezoelectric properties. Various kinds of pyroelectric detectors and ultrasonic transducers have been developed by employing these modified PbTiO, ceramics.

I. INTRODUCTION

Recently, pyroelectric infrared sensors have been videly used in cousumer electric appliances and other electric equipments such as microvave ovens, automatic door systems, human body sensors and burglar alarm systems. Pyroelectric infrared sensors show good sensing characteristics. Differing from photon sensors, they can be used at room temperature and their infrared response does not depend on the wavelength of the infrared rays used. The pyroelectric materials performance is represented by the figure of merit Fv, defined as P/ + Cv. whore, P. + and Cv are pyroelectric coefficient, relative dielectric constant and volume specific heat, respectively. Novadays, various kinds of pyroelectric materials, like Lilato, single crystal, are commercially available and used. Among them, PhliU, ceramics have been regarded as good

representation of the interior of the interpretation of the interpretation coefficient P, small dielectric coestant **, and high Corie temperature to. The present paper reports the procedectric and electrical properties of (Pb, Me) ((Co., 7)i1,7), tip0, coramics ((fe=8a, 3r or Ca),

2. EXPERIMENTAL.

Figure 1 shows the pyroclectric ceramics manufacturing process. Raw materials, PhO, TiO₂, CoO, MeCO₃, VO₃, MnCO₃ and NiO, were calcined at 900°C for 2 hours in air after weighing and mixing. The mixture were formed by diepressing and fired at 1100~1180°C for several hours. Because of the low firing Lemperature and small amount of PhO vaporization, in comparison with PZT (PhTiO₃-PbZrO₃) ceramic, the mixture was not fired in PhO atmosphere. Both surfaces of the fired samples were polished until the samples were 0.5 mm thick and their diameter was 20 mm.

TANDALIN MESSESSES SECTIONS

Usually, PbTiO, ceramic polarization requires a markedly high voltage and high Lemperature, more than 60kV and 2007C, respectively. Novever, (Pb, Me)- $\{(f_{\alpha_1}, V_{\alpha_2}), Ti\}0$, ceramic can be polled at lover voltage and temperature, 40~50kV/cm, 100℃, respectively, in silicone oil. Aging tests were performed for each sample. Pyroelectric coefficient P values were measured by the conventional system. Relative dielectric constant & values were measured by LCR meter (YHP-4261A) at Ikliz. Responsivity Rv and relative detectivity D* were measured under chopped light irradiation from He-Ne laser (Hughes Aircraft Co. Model 332111-PC) by signal analyzer (Ivatsu Sm-2100A) and a spectrum analyzer (Nevlett Packard 3582A).

The spontaneous polarization values were measured by the Savyer-Tover method. Using the system in Fig. 2, we have measured pyroelectric coefficient values.

3. RESULTS

Figure 3 shows pyroelectric coefficient P, relative dielectric constant ϵ and figure of merit Fv for $(\text{Pb}_{1-x}\text{Ca}_x)\{(\text{Co}_{1/x}\text{V}_{1/z})_{\bullet,\bullet}\epsilon\text{Ti}_{\bullet,\bullet}\}0$, as a function of Ca concentration. As Ca is introduced into PbTiO₂ ceramic, the pyroelectric coefficient increases to a great extent.

Curie temperatures and coupling factors for the $(Pb_{1-x}Me_x)((Co_{1/x}V_{1/x})\cdot \cdot \cdot \cdot Ti_{\theta-\theta})0$, system are shown in Fig. 4 and Fig. 5, respectively. From Fig. 5, it is found that these piezoelectric materials have an extremely anisotropic piezoelectric effect.

4. DISCUSSION

The improvement of pyroelectricity by the Ca introduction into PbTiO, host lattice may be attributed to the increase of the spontaneous polarization as shown in Fig. 6.

The large piezoelectric anisotropy of these ceramics may be understood when the piezoelectric properties are reduced from the electrostrictive coefficient and the piezoelectric constant d₂₁ disappears for a particular ratio of the electrostrictive coefficients and a certain degree of polarization.

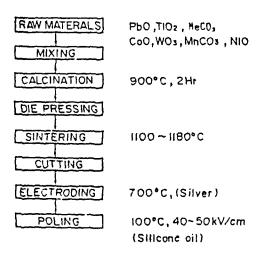


Fig. 1. Manufacturing process for (Pb. Me)((Co,,, V,,,), Ti)O, Ceramics. (Me=Ba, Sr. or Ca)

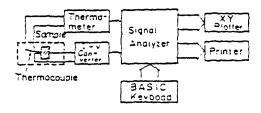


Fig. 1. Schematic diagram for measuring pyroelectric coefficient ?.

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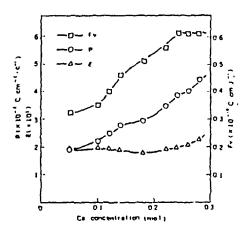


Fig. 3. Pyroelectric coefficient P, relative dielectric constant τ , and figure of merit Γ_V for $\{Pb_1=\chi, Ca\chi\}\{\{Co_1>\tau H_1>\tau\}\}Ti[O_1$ as a function of Ca concentration.

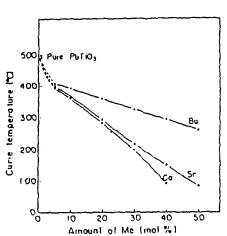
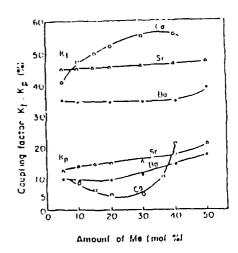


Fig. 4. Curie temperature vs amount of He for (Pb1-xHe x)((Co1-xH1-x is.stTis.ssTis.ssIO) system.

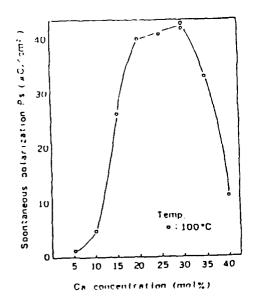


(3.3)

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Fig. 5. Coupling factors vs amount of He for $\{Pb_1=_n He_n\} \} \{Co_1 =_n H_{n-1}\}_{n=0}^n Ti_{n=0}^n + O_1$ system.



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Fig. (). Relation between apontaneous polarization Ps and Cs concentation of $(\mathrm{Pb}_{1-x},\ \mathrm{Ca}_{x})!\ (\mathrm{Co}_{1>1}\mathrm{M}_{1>4}\)!\ \mathrm{TijO}_{x}$ ceramics.

ARSTRACT

GRAIN-ORIENTED LEAD GERMANATE SILICATE CEPAMICS WERE PREPARED BY HOT-PRESSING METHOD. THE MICHOSTRUCTURE AND THE ELECTRICAL AND OPTICAL PROPERTIES OF GRAIN-ORIENTED SAMPLES WERE MEASURED.

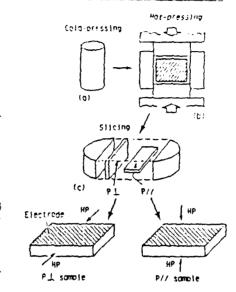
THE ANISOTROPIES OF 2 TO 4 TIMES IN THE PERMITTIVITY AND PIEZOELECTRIC AND PYROELECTRIC COEFFICIENTS HERE FOUND BETHEEN THE PARALLEL AND PERPENDICULAR DIRECTION TO THE HOT-PRESSING DIRECTION.

It was found that grain-oriented lead germanate silicate ceramics have highly active pyroelectric effect. The coefficient in the room temperature has $2.5 \times 10^{-2} \mu \text{C/cm}^2$ oc. has as same as that of LiTaO $_3$ single crystal and about 9 times as large as that of LiNaO $_3$ single crystal.

HOT-PRESSED LEAD GERMANATE SILICATE CERAMICS WITH A POROSITY OF LESS THAN 0.5 I SHOWED A TRANSMITTANCE OF ABOUT 50 I at a wave-length of $\delta\,\mu m$

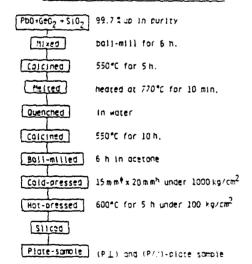
Hot-Dressed Lead Germunate Silicate Comple

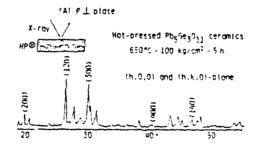
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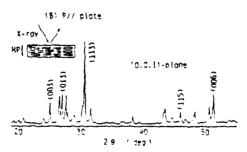


Preparation of Lead Germanate Silicate Ceramics

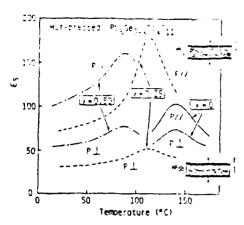
Compositin; PbsGes-xSixO11 -- PSSO / x



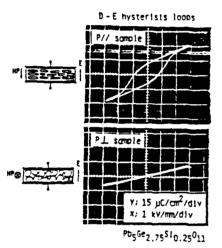




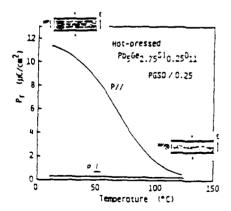
Typical Y-ray diffrantian patterns of hat-pressed lead germanate seramics.



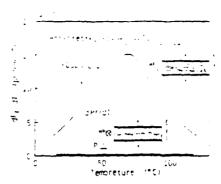
Temperature dependence of dielectric constant of hot-pressed lead germanate silicate ceramics.



B - E hysteresis loops for hot-pressed lead germanate silicate ceramics



Temperature dependence of remanent polarization of not-pressed lead germanate silicate ceramics.



Pyreelectric coefficient as a function or temperature for not-pressed lead germanate sillicate ceramics.

Pyroelectric properties of not-pressed Phewer 2000 on typical moterials

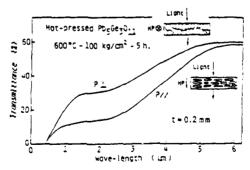
	Materials	7c (*C)	és .	والارام (والمسيامة) 10_4	0F/01Esco (A-m/W) x10 ⁻²
Cerant: s	PGS0/0.25	112	71	3.9	2.2
	Poeueyull	177	- 40	د . ن	0.52
	PS(Zr, 11103	300	450	3.1	0.24
	PDT 103	470	200	6.0	0.94
Crystal	762	49	35	4.0	4.6
	LITOO3	660	54	2.3	2.3
	LINOO3	1200	30	0.4	0.46
Ē	PVF ₂	120	n	0.3	1.2

^{*.} this work Poevez 75010 25021 ceronics

Pletoelectric properties of not-pressed ${\sf Polebes_{-x}Si_xO_{\underline{11}}}$

x +== 11	0.0	10	0.2	5	0.5	D
Samo Le	P//	• 1	P//	_•⊥	P//	P⊥
Es	35	25	71	28	105	53
KO	0.05		0.10		0.04	
(an	1020		950		1450	
k11	0.03		9. D6		0.02	
011 1=10-13-201	2.12		7.02		2.98	
933 1410 - JVM/#1	5.84		22.33		3.21	
\$11 1818 ⁻¹² 4 ² /HI	17.3		17.7		18.1	
2 ⁷⁷ (#18_ ₁₁ #,\#)	0.32		0.32		0.32	
Tc 1981	: 42		112		68	

Pojed: 20°C-30kV/cm-1 h.



Datical transmittance as a function of wave-length for grain-oriented lead germanate ceramics.

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FRACTURE BEHAVIOR OF CERAMICS USED IN MULTILAYER CAPACITORS

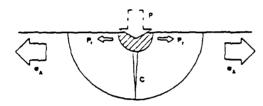
Therese L. Beker and Stephen W. Freiman National Bureau of Standards Gaithersburg, MD

EXPERIMENTAL PROCEDURE

Material - Various capacitor compositions (No electrodes)(AVX)

Form - 25mm squares, 1-2mm thick, as-fired

Test-indentation fracture (bisxisi fiscure)



DYNAMIC FATIGUE

Assume $V = V_0 (K_I/K_c)^N$

then: $\sigma_f = (\lambda' \hat{\sigma})^{(1/N'+1)}$

where N = 4N'/3 - 2/3

For isotropic , homogeneous material, e.g. glass:

obtain ;

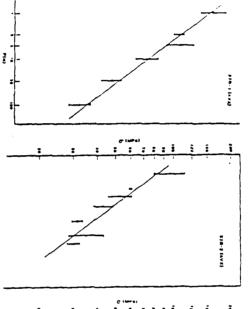
Kc = η (Ε/Η)" (σ, P")"

For polycrystalline ceramics :

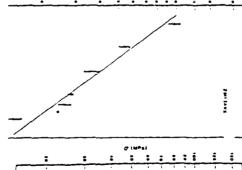
K = K 130trapic + K microstructure

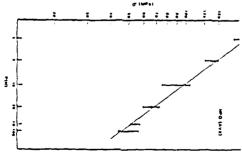
Where

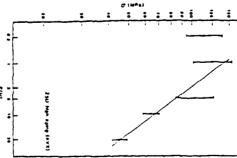
Kmicrostructure = f(C/G)



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FRACTURE BEHAVIOR OF CERAMICS USED IN MULTILAYER CAPACITORS

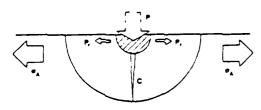
Theresa L. Baker and Slephen W. Freiman National Bureau of Standards Gaithersburg, MD

EXPERIMENTAL PROCEDURE

Material - Various capacitor compositions (No electrodes)(AVX)

Form - 25mm squares, 1-2mm thick, as-fired

Test-indentation fracture (biaxial flexure)



DYNAMIC FATIGUE

Assume $V = V_0 (K_I/K_c)^N$

then: $\sigma_f = (\lambda' \hat{\sigma})^{(1/N'+1)}$

where N = 4N'/3 - 2/3

For isotropic , homogeneous material, e.g. glass:

K= χPC-3/2 + ΨσC"2

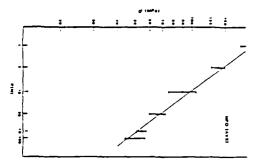
obtain :

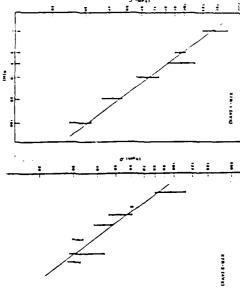
Ke = η (E/H)" (σ, P")"

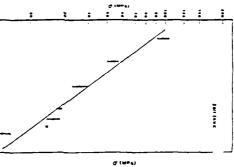
For polycrystalline ceramics :

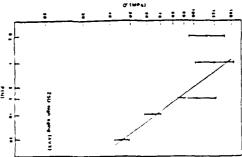
K = K Isotropic + K microstructure

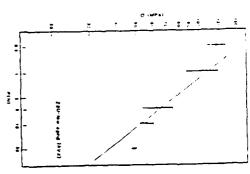
K_{microstructure} = f(C/G)

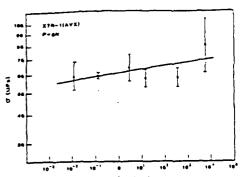


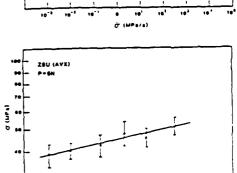


















X78 K. 10



250 K_{ic}+0.75



HPO K . . 1

CONCLUSIONS

- K_{ic} and N depend on composition and microstructure
- •K_{IC} correlates with degree of crack deflection
- Preliminary data indicates correlation between dielectric aging and internal stresses

Compositions and Properties of Capacitor Ceramics

Designation	Composition	Grain Size (um)	KIC (MPam1/2)	<u> </u>
NPO	Rare Earth Oxides	1-3	1,4	99 ± 49
X7R-1	BaT10 ₃ (B1)	12	1.0	85 ± 60
X78-2	BaT103	\$1	0.7	158 ± 212
25 U	BaT103	3-7	0.8	58 ± 10
ZSU "high" aging	BaTiO3	3-7	1,1	
Z5U "low" aging	BaT103	3-7	0.9	

¹ Major constituent

5.5

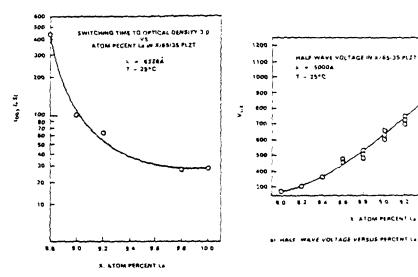
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Compositional Influences on PLZT Switching Properties

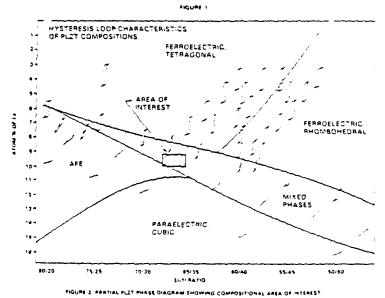
B. KOEPKE, F. WALLENHORST and J. KYONKA Honeywell inc., Minneapolls, MN

ABSTRACT: Half-wave voltages, polarization and capacitance were measured for a series of PLZT samples with varying La contents and Zr/Ti ratios. These parameters, particularly half-wave voltage, are critical in the design of active PLZT optical components. Lower values of half-wave voltage are highly desirable. This work establishes that as the La content exceeds 9.4 atom % and as the Zr/Ti ratio exceeds 65/35, undesirable increases in hall-wave voltage will result.

7.

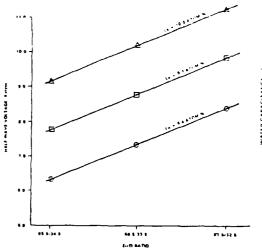


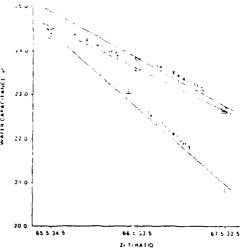
AL SWITCHING TIME TO OPTICAL 2 O VERSUS ATOM PERCENT LA



- 88 -

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ME 3. HALF-WAVE VOLTAGE DEPENDENCE OR LA CONTENT & ZITTI RATIO

FIGURE S. WAFER CAPACITANCE DEPENDENCE ON LA CONTENT & LI TIMATIO

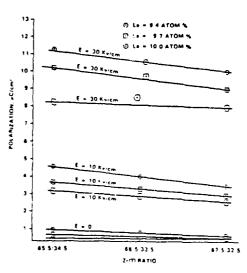


FIGURE 4 POLARIZATION DEPENDENCE ON ZUTI RATIO

<u>Discussion</u>
This work shows that, as the $\mathbb{Z}n\mathbb{T}$ ratio is raised above the 65.35 level, the nall-wave voltage raises for 9.4 arom percent and higher La contents. Switching time measurement scatter was such that differences between samples were not detectable. The such that differences between samples were not detectable. The data did not, however, suggest a significant trend over the compositional range tested. Figure 2 shows that the water colocitance and therefore detectric constant is inversely related to both the La content and the \mathbb{Z}/T ratio. Potarization is shown in Figure 4 to be inversely related to both La content and \mathbb{Z}/T ratio. The results of this work indicate that \mathbb{Z}/T ratios of less than 65/35 along with La contents of less than 9.4 atom 66 should be exported. If appears that lower hail-wave voltages can be achieved with probable minor imbaction switching time out at some cost in higher detectric constants and polarization values.

Electromechanical Failure Predictions

R. C. Ponanke and P. L. Smith
Office of Naval Research
and

S. W. Freiman National Bureau of Standards

Table 1

Electromechanical Conditions

Device	Electrical Field	Strain Condition	Stress
Capacitors Microdispersive Devices	Static	Static	Stresses at Flows Increased by Electric Field Concentrations
Plezoelectric Transducers	Cyclic	Cyclic	Uniform at Cross Section
Electrostrictive Transducers			Uniform at Cross Section
a) blesed	Statle + Cyclic	Cyclic + Static	
b)con~blosed	Cyclic	Cvelle	

For Superitical Crack Grawth

Crack Velocity, V= Va (K, /K,c)"

then
$$\frac{dt}{dc} = (\sqrt{K''}) K''_N$$

where dis crack length

Re-arranging

Integrating $t_{i} = \int_{0}^{t_{i}} dt = \left(K_{G}^{N}/N_{G}\right) \int_{Q_{i}}^{Q_{i}} K_{i}^{N} da$

where K, = f(a)

Electric Field Enhanced Stress at Crack Tips

Estimation of electrical field and strain field in ceramic capacitors

With solution of the spatial potentials within the dietectric the electrostricture strain may be calculated Tia:

The local ennancements of the electrical field within a parallel plate capacitof are summafized below

inside ci llaw exterior of flaw

- X

Closed -total	()	1
• roughened	23	22
roughened W/prowuding Voids	5 (20
Diamond void	3.2	19
Square void	17	"—————————————————————————————————————
Dejamination 60 Unickness	1)	36
End of Conductors		12
Celemmation on		
ton ductor 193 delam	9.2	**
United the		

Electrostriction Calculations

Polarization and Electrostrictive strain

$$P_1 = c_0 \chi_{ij} \Xi_j \quad \text{and} \quad c_{ij} = \mathcal{Q}_{ijkl} P_k P_l$$

+ For ${\tt EaTiO}_3$ in isotropic form the above relations

$$\begin{bmatrix} \epsilon_1 \\ \epsilon_2 \\ \epsilon_3 \\ \epsilon_4 \\ \epsilon_5 \\ \epsilon_5 \end{bmatrix} = \begin{bmatrix} Q_{11} Q_{12} Q_{12} & 0 & 0 & 0 & 0 \\ Q_{12} Q_{11} & Q_{12} & 0 & 0 & 0 & 0 \\ Q_{12} Q_{12} & Q_{11} & 0 & 0 & 0 & 0 \\ Q_{12} Q_{12} Q_{11} & 0 & 0 & 0 & 0 \\ Q_{12} Q_{12} Q_{13} & 0 & 0 & 0 & 0 \\ Q_{12} Q_{12} Q_{13} Q_{14} & 0 & 0 & 0 \\ Q_{12} Q_{12} Q_{13} Q_{14} Q_{$$

Courtesy: W. B. Carlson The Pennsylvania State University



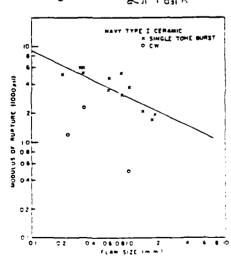
$$K_{s} = \frac{p}{\sqrt{\pi \alpha}} \left[\frac{1-\alpha}{4} y_{0} \frac{\partial}{\partial y_{0}} \right] \left[\frac{\alpha}{\sqrt{\alpha^{2}-z_{0}^{2}}} + \sqrt{\alpha^{2}-z_{0}^{2}} \right]$$

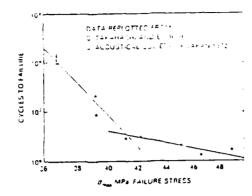
where
$$\alpha = \begin{cases} 1/2(1+U) & \text{Plane stress} \\ 1/2(\frac{1}{J-U}) & \text{Plane strain} \end{cases}$$

Cyclic Strength Eehavior

Dynamic Strength Equations

Ring
$$G_{Rak} = \frac{T_p}{Q + 41h}$$





STRESS CORNOSION EXPONDITS

for

DIELECTRIC and PIEZUELECTRIC

CENTRICS

Material	ū
Bal'103	60-70
ва _х Са _{1-х} Т1 _{1.03} 03	23-38
FZT	40-60
Capacitors	
รรบ	40-60
HPO	100
YELV	80-15u

Cyclic Electrostrictive Strength

Electric Field Biased Electrostriction

Experimentally Determine Effective d Constant

$$d = k \left(\xi S_{H}^{\epsilon} \right)^{\nu_{\ell}}$$

k Determined Experimentally from Resonance and Antiresonance Frequencies

Calculations Are Made Similar to Plezoelectric Case

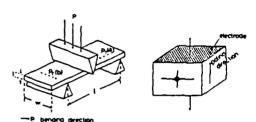
Non Bigsed Electrostriction Is Highly Nonlinear and Needs Further Analysis

Combined Effects Due to Mechanical and Electrical Loads and Internal Microstructural Stresses
Must be Considered

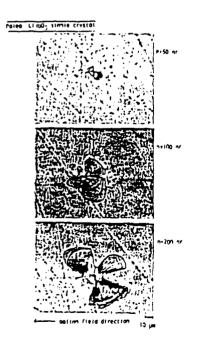
:5

The relation of anisotopy between cruck begal and fracture toughness in polal PLET and modified POT. Os
T. Tamameto et. al.
National Referse Academy

three point bonding test and microladentation test







Crack and indent of poled Linbo, single crystal



Crack and indent of poled modified PbT10, ceramics

Calculation equations of E_{le}

te le		
E ₁₆ +0.073FC '4.5	-	1.
E1c-4.036c0.4p0.6a-4.7(c/e)-1.5		Marshall et. al.
x1c=0.020E0.5p0.3a=0.3(c/e)=1.3		Love et.al,
E: Yampi wedulus P: indend load,		
مزحت - مز		
ule- 2在中		
$x_{1e}^{-2} / (\sigma_{ex} - \sigma_{i}) / E = x_{1e}^{-eff} -$	1/5 4 6	

ale Te Varie

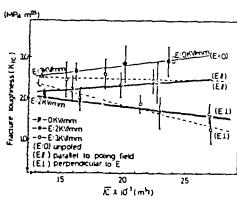
If the sample has an intermal stress \mathcal{T}_i , k_{1c} change by the square root of crack length, \mathcal{E} .

(Pb,Ca)TiO, ceramics

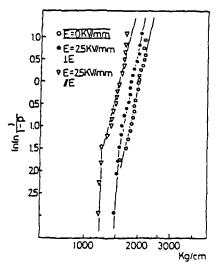
coupling factor	elastic constant (x10°12±271)	noisson's ratio
E _p : 0.043 E _{p1} : 0.027 E _t : 0.524 E _{p3} : 0.541 E _{p3} : 0.541	$\begin{array}{cccccccccccccccccccccccccccccccccccc$	Ø . 3.205

PLST 2/50/50

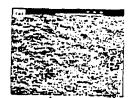
templier factor	thatic content (ALC) (2-) an	2012100.11 10111
Kg : 2.34	st : 12.3	01: 1.353
k ₂₁ : J. 5	5. 15.	



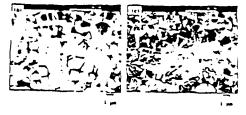
frecture toughness as a function of square root of crack length in peled medified PSTID, coranics



weibull plots of failure stress of unpoled and poled modified ${\tt PofiO}_{\tt j}$ ceramics



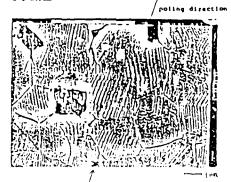
Department of fracture change 10 pm



Fracture surface of poled modified PhTiO



Fracture surface of (a) and (b)

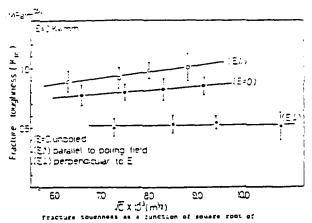


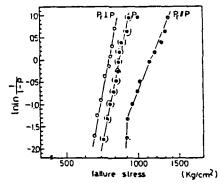
= 2KV/mm PLZT 2:50/50



Indent load=700g

<u>.</u>





Weibull plots of failure stress of poled and unpoled PLZT (2/50/50) ceramics



, t 2,g 3	#le (E # 1 H 1/H 1.5	Fic E Li 1.5 1.5	c(E f)	C(E T)	c(E # 1/c(E 1)	ei£ / i	CIE AÍ	elt e ficiali
10	2,361	1.640	0.541	0.728	1 4	0.527	0,610	1 15
23	2,362	1.650	0.381	6.526	1 4	0.400	0,619	1 15
23	2,272	1.650	0.253	6.273	3 2	0.244	0,276	1 15

prindent load, $s_{1c}(t_{\beta}) : s_{1c}$ parallel to the poling field $s_{1c}(t_{\beta}) : s_{1c}$ perpendituler to the poling field $c(t_{\beta})$; creek length perallel to the poling field $c(t_{\beta})$; creek length perpendicular to the poling field

Idenal stress = zero

Anisotropy of crack length →Internal stress

Mechanical and Dielectric Failure of BaTiO₃ Ceramics

A. KISHIMOTO, K.KOUMOTO, and H. YANAGIDA

Department of Industrial Chemistry,

Faculty of Engineering, The University of Tokyo,

7-3-1 Hongo, Bunkyo-Ku, Tokyo 113

ABSTRACT) A usual method for mechanical strength measuremen: requires a lot of test pieces and time, which should be inconvenient from the technological point of view.

The present paper reports the alternative method to predict the mechanical failure probability, utilizing the analogy between mechanical and dielectric strength distributions, without spending a lot of test pieces.

Sample preparation

Grain size distributions

Measuring Apparatus

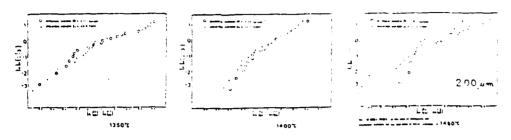
THE LOCALITICAL CHARLES SIZE DISTRIBUTION OF BATIOS

1300°C | 1300

Fig. THE APPARATUS FOR DICELECTRIC STRENGTH (EASURETER)

Lety expression associated was a strength of the control of the entire en

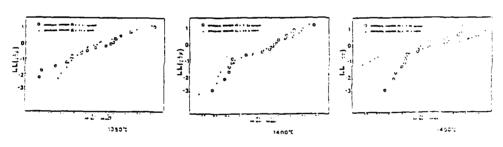
heasured at room temu.



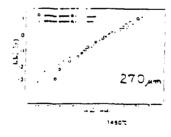
2. Correlation between both failures depends on weak spot distribution.

 κ_{IC} changes above and below Curie temp. while crack size remains the same.

Measured at 145°C



3. Effects of thickness on Weibull plots.



Discourt Section (Sections) Process (Section Process Sections) Because (Weddins) (Section (Section))

DISCUSSION) The fracture origins in both failures are the same. (?)

Crack stress concentrator field concentrator

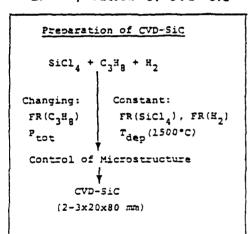
Toughening of Ceramics by Crack Tip /Stacking Faults Interaction

K. Niihara, The National Desense Academy T. Hirai, RIISOM, Tonony University

1. Introduction

The intent of this work is to clarify the microstructure characteristics of CVD-SiC ceramics and to examine their mechanical properties such as fracture strength and toughness up to 1500°C. Particular emphasis is placed on the understanding of characteristic superfine structure effects on mechanical properties, i.e. fracture toughness.

2. Preparation of CVD-SiC



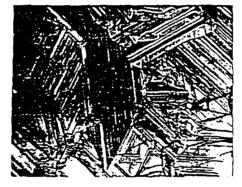


Fig. 2 Typical microstructure of CVD-SiC

3. Superfine Structure

Microstructure of CVD-SiC

Structure: 8-type (but stacking)
Density: 99 to 100% of Dth
Preferred Orientation: (220) or (111)
Grain Size: 0.1 to 1000 um
Impurity Phase: No (no free C)
Grain Boundary: No impurity phases
Color: Coloriess, Yellow, Brown, Black
Translucent

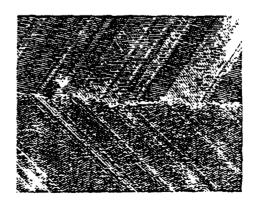
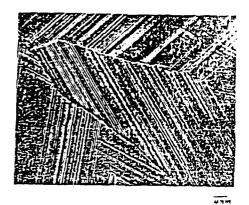


Fig. 3 Righ resolutional lattice image of grain



X

3

53.5

Fig. 4 High resolutional lattice image of multiple

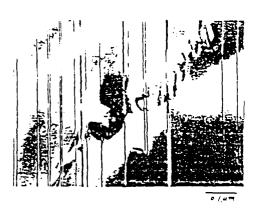


Fig. 7 Small plastic deformation at crack tip for CVD-Sic.

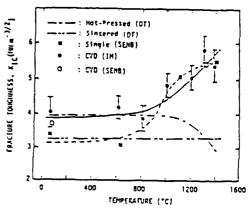


Fig. 5 Temperature dependence of fracture toughness for CVD-SiC.



Fig. 8 — Small plastic deformation at crack tip for CVD-TiC.

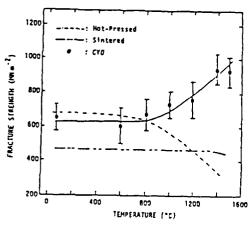
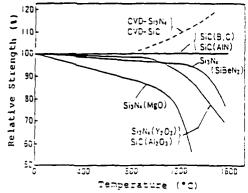


Fig. 6 Temperature dependence of fracture strength of CVD-SiC.



ACCOUNTAGE PROPERTY (NOT CONTRACTOR OF CONTR

Fig. 9 Temperature dependence of fracture strongth for various SIC ceremics.

Ceremics	Toughness (MY/a2)
(a) Grain-Boudary Control	
GP-S13N4 (SIBeN2, S102)	2.9
HP-\$12.9Be0.1H3.800.2	1.3
Sielon	3.1
CAD-213HP	3.2
PS-SiC(B, C)	3.5
HP-S1C(Alm)	3.5
CVD-S1C	3 - 3.5
(b) No Grain-Boundary Control	
HP-S13N4 (MEO)	5 ~ 6.8
HP-S1C(A1203)	6 - 6.0

GF: gas pressure sintering, HP: hot-pressing PS: pressureless sintering, (); sintering eids

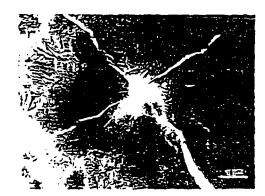
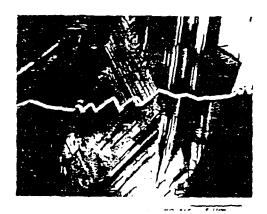


Fig. 10 TEM observation around indentation for CVD-Sic.



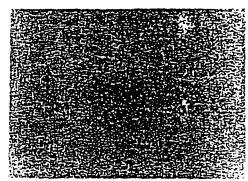


Fig. 13 High resolutions! Interco image of grack tip



Pag. 15 you adventure for CVP-SIC with low excesses fours



Fig. 16 TER STATESPROPE TO CHE-SIG WILL ION SCANIET A COM-



Fig. 15 TER alteregraph for CVD-biC with bith density ** Cod according shall the code mary \$1.2 ().

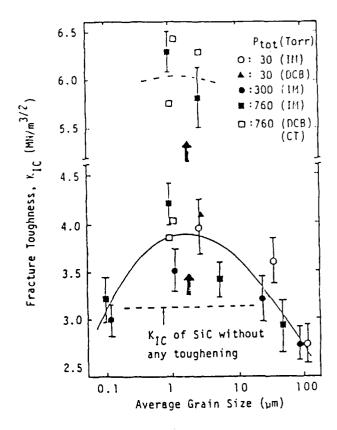


Fig. 18 Fracture toguhness for CVD-SiC.

6. Conclusions

- (1) Highly pure and Dense SiC without any impurity phases at grain boundaries were prepared by CVD.
- (2) Toughness and strength of CVD-SiC increased above about 1000°C due to small plastic deformation at crack tip.
- (3) Toughness of CVD-SiC was extremely improved by introducing stacking faults into grains.

New toughening mechanism: stacking faults-crack tip interaction

PHOTOFERROELESTRIC EMPROTS IN PLIT CERTAINS

GENE HAFFTLING

MOTORULA, INC., ALBUQUEFGUE, NEW MEXICO, U.G.A.

ARTIFACT

Several non-memory PLT compositions were evaluated for their resistance to the compined effects of high electric field, elevated temperature and night intensity light elevated. All materials entitled behavior which client their performance under frese conditions. It was found that complete concellation of the electropotic effect ion activated shutter degrading to an off condition; could be obtained under certain conditions. This was believed to be due to either about or thermally excited space charge acreaning out the doolled field. The anatomic client space charge effects could be essentially elements by means of ac rather than ac voltage memoration.

LUTRODUCTION

Since the edrly 1970's when the transparent, silb-loop ferroelectric PLT materials were first utilized in switter devices, it was noted that these adterials were limited on their performance by residual memory these adterials were limited on their performance by residual memory therement amorifested in a time-dependent deteriaration of the OFF construm Subsequent research investigations have contributed greatly to an understanding of these ohenament which are generally classified as (1) festiously memory effects requiring from a field-induced ferroelectric state ond (2) space charge effects produced by the photoexcitation of charge corriers and their advances under the influence of an electric field. The present study reports on some opserved effects in the latter category as they relate to SFE idenfarroelectric) agreeneds in transverse-mode, shutter devices.

EXPERIMENTAL

Not pressed, bolished and electroped samples of PLIT compositions \$46575.9.576575. 765753. 870730 and 15/40/10 were selected for study the vocaus pepalities, Cr-Au. single-sized, surface electrodes consisted of an interductful array of electrope electrope such a dops romaing from 0.05 ms to 0.25 ms. Electrical and electropottic Prosuments were more on the samples as a function of electric field, temperature, time and light emposite. A high intensity mercury are 10mb 115 ms/cm² most used as the light source in conjunction with various filters ranging from 300 ms to several agreems.

Some charse and photoconductivity measurements were canducted on the setup shown in Figure 1. These measurements were taken and recorded while under visual apservation of a modnification of \$100.

RESULT

It was found that (1) the PLIT materials evaluated in this study were mighty susceptible to the Complined effects of high intensity light exposure and high electric fields, (2) the effects are more pronounced at temperatures hear or above To consider the dielectric constant. 65°C for 9/65/35) and (3) the effects are time dependent and will always anneal but at a rate which is dependent on immercture and light emposure A tybical set of curves are shown in Figures 2, 3 and 4. As noted, the virgin material is symmetric about the zero E axis, whereas the materials subjected to either a positive or negative play while Hillmingted line usual situation in a shutter device) exhibit varying degrees of light intensity assumetry. The relaxation time for this effect or jodic for PIT 9/65/35 was found to be approximately 5 seconds (UV .igns on) consequently, on azzyvated shutter would be totally compensated (turned OFF) by the enotoexcited space Charge field in this time frame $-^*\mathrm{mis}$ deleteflous effect was essentially eliminated by driving the shutter with an ac voltage at 30 kg of can be seen in Table 1 Figure 5 sumbrizes these results in a play of contrast ratio (CR) vs. temperature

Photoconductive effects in these mater of silvere displayable to monitoring the voltage across of 20 PD. Testistar connected in series with the shutter and the cover subdive histories is above them on this voltage was additing to the shutter without including to the or no steady state victage was diversored across the resistor nowewhere the capital source was diversored across the resistor nowewhere the capital source was turned on several neuroposts to roots now ment the capital source was turned on several neuroposts to roots of resist of the conduction of photoexities sooke thore across the pack of the interdigital electropes. The voltage those shown in figure constitute of the conduction of photoexities should be the predominant of the vortage interdigital electropes. This effect was found to be the predominant of the vortage found rate the predominant of the vortage forms and the vortage forms and the vortage forms across sociated with the short workength region from \$20,150 ns inhough the vortage forms such as all the predominant of the vortage forms such as all the predominant of the vortage forms such as all the predominant of the vortage forms such as all the predominant of the vortage forms such as all the predominant of the vortage forms such as all the predominant of the vortage forms such as all the predominant of the vortage forms such as a predominant of the vortage forms such as a predominant of the vortage forms and the vortage form

١.

CONCLUSIONS

- The PLT materials are highly complex in nature and exhibit a
 wide veriety of electrical, detical and theregily activated effects
 such as the anothypitals effect, phosphophaction, pyroelectricity
 anothypinaced indice charge, shotechromic behavior and a phosphophace change in index of refraction. PCID town or mess effects
 are one directly to the Chancel its Chamerry and defect concentration, yearned.
- 2 Residual memory effects in the sise ood indimembory Pull 5 are preadminate at food comberature increas the anatoresc less social charge effect is significant at elevated (DTC 1,000C lemberatures)
- A Mostous in confrost ratio for shutter devices exists in the temperature range from WG-6070
- 8. Photocompution in the $f(\mathbb{Z}^n)$ is is about sensitive to unlikewed entitle in the remain of \$20-580 has
- hanvior the degraphing effects in the full materials for peessentially eliminated by means to accrather into a smetar an

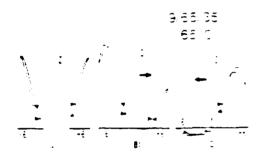
TABLE '

CONTRAST RATIO VALUES OF A 3 65 35 SHITTER

ACCRE	SSING	MIN	U*E	30 M	~~~ { S	3	47		
CONDITIONS	HOMS	25%	20.0	23"	cc*:	21-	-00 ℃	29.7	\$7.°
	ec		3	2"	•	-	-	-	
	4.5	_	208	23	-62	2.0	٠,	22	91
JV	0.5	9.9	6.5	12		-			
JEF.	15	::	232	2.3	5.2	i.c	1:	·-	٠,٠

NOTE ELECTRODES - OSMM WIDE FORMM JAP DE - OPERATING VOLUTALE - 2007

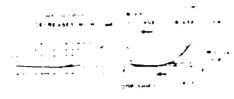




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Programme take thatak terkst (*)

of Three Samples

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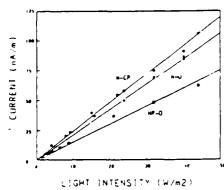
 $a^{\perp} = a_{+} (1 + a_{-})$

F. = 1,./3

= (a/di) (1/(1+A1))

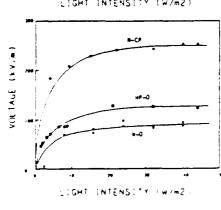
Photovollaic Effect

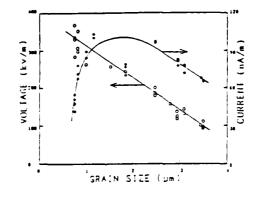
in Three Samples, N=0, HP=0 and N+CP

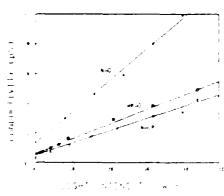


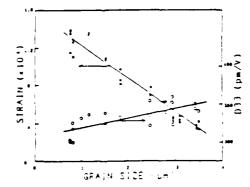
SAMPLE	6, (p S / m)	/5 (# 1 U * m+/=)	K (nAm/w)
#-O	46.4	4 69	2. 12
нР-0	20 .	4.65	1. 60
4-CP	17 0	4. 60	2. 40

Grain Size Dependence of Photostriction

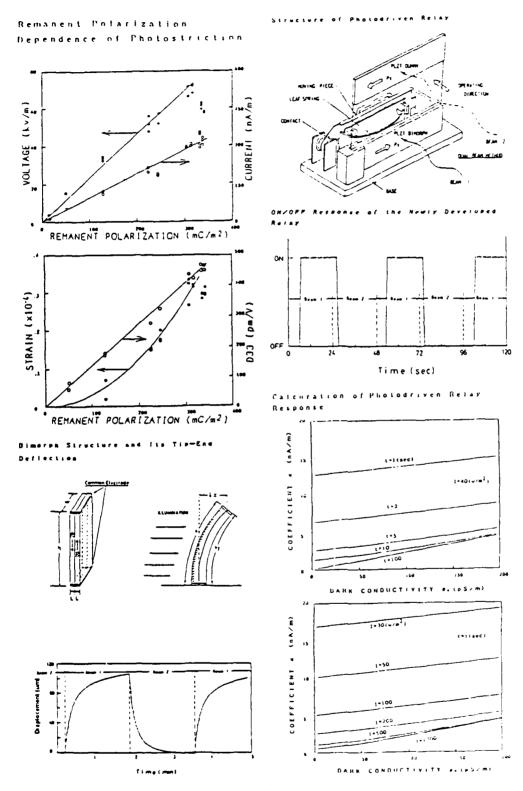








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Analysis of Photodriven Felay

Typeend Deflection of Bimorph

$$-\delta X = \frac{3}{4} \cdot \frac{\ln (dx)}{L} \cdot U \tag{4}$$

Longitudinal Electric Field

generated by the charge on the Electrode

$$E(t) = (J_{**} R/h) \cdot (1-exp(-1/CR))$$
 (2)

Photocurrent and Photoconductivity

$$J_{**} = k \cdot i \tag{3}$$

$$\sigma^* = \sigma_* (1, + \beta \cdot 1) \tag{4}$$

Tip-end Deflection as a Function of

Light Intensity and Time ((rom (1)-(4))

$$\delta X (t) = \frac{3 h^2 \kappa d_{12} l}{4 L \sigma d (3L + B l)} (1 - exp(\frac{-\sigma d (3L + B l)}{3L c_{11} c_0}))$$

Parameters

h=0 02 (a), $\xi=2x$) (i.e. (a), $\xi=4$ is (yield

 $6n = 350 \times 10^{-7} / (6/8), \quad C_{11} = 2.0 \times 0.$

 $0 = \zeta - 6x + (0 + (e^{-\zeta}), -\xi + (1 + \pi + 5x + 0) + (e^{-\zeta})$

PLZT THIN FILMS ON MgAI:O./SI SUBSTRATE S.MATSUBARA,Y.MIYASAKA,N.SHOHATA and M.YOHEZAWA NEC Corporation,Kawasaki,JAPAN

SUMMARY

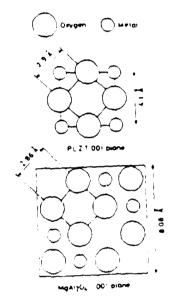
- . PLET FILMS WERE SPUTTER DEPOSITED UNITO (GGTIMGAI, O. S.
- EPITAZIALL GROWTH OF PLZT FILMS ALONG THE <401> AXIS
 OF THE MGALIGE FILMS WAS DESERVED.
- . THE CRYSTALLHUITY AND THE LATTIC CONSTANT DEPENDED ON THE LA CONTENT OF THE TARGET.
- . DELECTRIC CONSTANT WAS MEASURED WITH A MIS STRUCTURE 1 - 488 AT 100 KHZ

PLLT MgANOSS STRUCTURE



Dernies Id. AR's





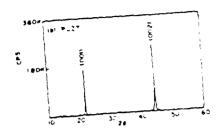
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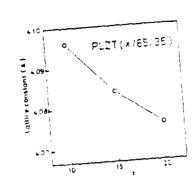
100" PLANES OF PLT AND MGAISO.

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X-RAY DIFFRACTION PATTERN FOR PLET MOAISUAS



LE CONTENT DEPENDENCE OF LATTICE CONSTANT



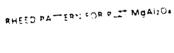
PLIT

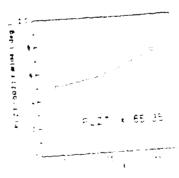


MgAirOa

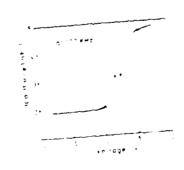


SURFACE MORPHOLOGY OF PLIT FILM





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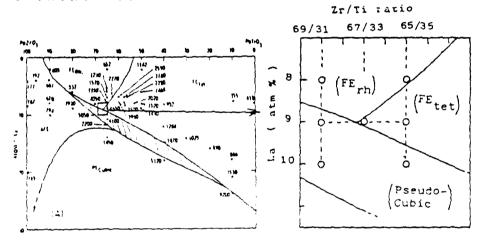
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SOME ELECTROOPTIC PROPERTIES OF

PLZT CERAMICS

K. Hikita, M. Hirama, Y. Tanaka and M. Ono R&D Center, Ceramics Mitsubishi Mining & Cement

1 INTRODUCTION



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According to the phase diagram of PLZT, phase boundaries among two ferro-electric phases and a pseudo-cubic phase are crossed near the composition of 19.67,1331, and near where the composition sition of .9.65.35... which is suitable for optical shutter applications.

However, the electrooptic properties have been scarcely studied around the crossed point. Then the present study reports the dielectric and electropotic properties in this region.

2. EXPERIMENTAL PROCEDURS

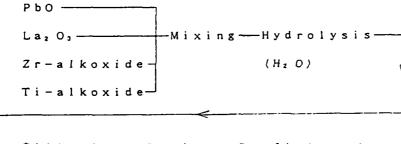
1) Sample Preparation

*Composition; Pb_{1-x} La_x (Zr_y Ti_z)_{1-x/4} O₃

x = 0.08, 0.09, 0.10

y = 0.65, 0.67, 0.69

*Processing of PLZT powder



— Filtering — Drying — Prefiring —> (700 ~900 ℃)

---Ball- --- Drying --- PLZT · Powder

Milling

(in acetone)

*Hot Pressing and Annealing

(Two-Stage Method)

Hot Pressing; 1200°C, 5llr, P=100 kg cm²

Annealing; 1200°C, 20Hr.

2) Measurement

* XRD

Crystal phase

*D-E Hysteresis Loop

AC electric field; 2kV/mm, 50Hz.

Sample; 5x5 mm', thickness 0.25 mm

*Birefringence (\(\Delta n \)

Polarizing Microscope, Senarmon

Compensator

Sample: Mirror-polished PLZT

thickness 0.5 mm

gap between electrodes 0.5 mm

Determining the rotating angle of

Analyzer \longrightarrow Retardation ($\Gamma = \Delta n \cdot 1$)

Quadratic electrooptic coefficient

, R, was determined by following eq.

 $R = -2 \triangle n / n_1^3 E_2^2$

where, n₁ : refractive index

E, : electric field

- 3. RESULTS and DISCUSSION
 - 1) D-E Hysteresis

(X, 69, 31); The loop changed to slim

with increasing in La

,

ratio

(X/65/35); The same tendency.

(9/Y/Z) : The loop changed to slim with increasing in Zr/Ti ratio.

- *Ec and Pr decreased with increasing in both La ratio and Zr ratio.
- *D-E hysteresis loop also became
 slim with increasing temperature.
- 2) Birefringence and Quadratic electrooptic coefficient (R)

(X/69/31); Memory effect was observed for La 8 atm%.

Quadratic electrooptic effect was shown for La

9 and 10 atm%.

(X/65/35); the same tendency.

(9/Y/Z) : quadratic curves changed to flat as $Z\tau$ ratio increased.

Quadratic electrooptic coefficient increased with decreasing in 2r ratio.

*A little hysteresis was observed in the quadratic curves, which decreased with increasing in both La ratio and Zr ratio.

*The difference between the experimental results and reference data
of quadratic electrooptic coeffici
ent was considered due to thickness
of the samples.

3) X-Ray Diffraction

Crystal phases were examined by means of XRD. However, apparent difference was not observed on the λ RD patterns, therefore it was so hard to determine the crystal phase only

by means of λRD

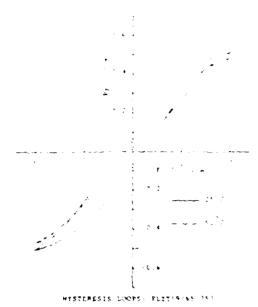
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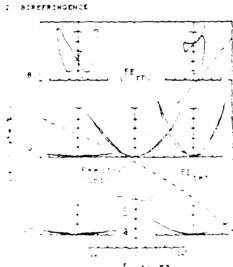
1. C-E OBSTEPESIS LOOFS

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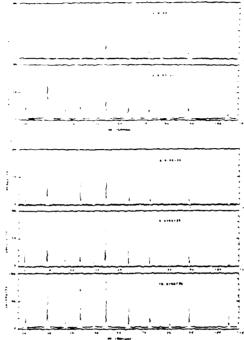




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ONORROW MERCHANIC BOOMSOND BOOK

SUMMARY

Discontric and ejectrooptic promperties were studied for the botcressed lanthanum modified lead
circonate titanate PUETT ceramics
near the composition of (9/67/33).
where three phase boundaries were

The hydrenesis loop became slim with increasing in Tr. Tr. fixting. for the composition of 1972 Tr. Tr. fine hydrenesis loop also changed to allow with lacreasing in MA ratio for poth searcles of X 65.25 and X 48.1.

The awaretic electropetic coeffice coeffices are were operated with increase the process of the coeffice of th

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DIELECTRIC PROPERTIES OF SPUTTERED POLYCRYSTALLINE (Pb.La)(Zr.TarO, THIN FILMS

K. WASA, H. ADACHI, and T. MITSUYU

Central Research Laboratories, Matsushita Electric Ind. Co., Ltd.

Yagumo-Nakamachi 3-15, Moriguchi 570, Japan

ABSTRACT: Thin films of polycrystalline $Pb_{1-x/100}La_{x/100}^{(2r}y/100^{Ti}z/100)^{1-x/400}$ o_{3} , FLIT, were prepared on a sapphire substrate by rf-magnetron sputtering from the PLIT sintered powder target. The sputtered films show a perovskite structure and exhibit a dielectric anomaly. Dielectric properties were discussed in comparison with bulk ceramics.

1. INTRODUCTION

Thin films of ferroelectric materials are of much interest for a fabrication of novel fuctional devices. The single crystal films of the quaternary solid solution of $Pb_{1-x/100}La_{x/100}(zr_{y/100}Ti_{z/100})_{1-x/400}$, PL2T(x,y,z), were extensively studied for making an electro-optic devices . Recently we have prepared polycrystalline thin films of the PL2T(x/y/z) by rf-magnetron sputtering and evaluated their dielectric properties.

2. PREPARATIONS AND MEASUREMENTS

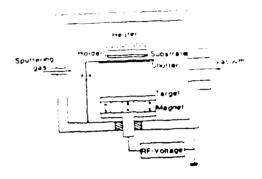
The PLTT thin films were deposited by the sputtering from sintered PLTT powder target. The sputtering conditions are shown in TABLE 1. Sapphire wafers were used as the substrates. The substrate temperature was kept at 500 to 700°C. The dielectric properties of the sputtered PLTT films were evaluated in a sandwitch structure, Au thin film top electrode/sputtered PLTT films/TiN thin film base electrode, prepared on the sapphire wafers. The TiN base electrode was sputtered onto the sapphire wafer prior to the sputtering deposition of the PLTT films. The Au top electrode was deposited by a conventional vacuum deposition after the deposition of the PLTT films.

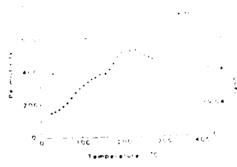
3. PESULTS AND DISCUSSIONS

The sputtered PLTT films showed a polycrystalline form with the perovskite structure. Their room temperature permittivity was ranged from 100 to 700 depending on their composition, and dielectric loss, tan 8 0.01 to 0.1. The frequency dispersion of the permittivity was 5 to 15 % from the frequency range of 10 kHz to 1 MHz. These sputtered films exhibited a dielectric anomaly. This results for the PLTT films sputtered from PLTT(9/65/35) target are \$10-10 Fig.1.

There I shows a variation of the dielectric properties with the La restration in the target of PLIT(x/65/35). It is seen that the permittivity as a maximum at the La concentration of about 10%. This may suggest that are appears a phase change from rhombohedral/tetragonal/cubic by the increase and concentration similar to the case of bulk ceramics. The dielectricatementarize observed in the sputtered films was 220 to 280°C which are the dielectric-anomaly temperature for bulk ceramics. This was no the difference of the net composition between bulk ceramics.

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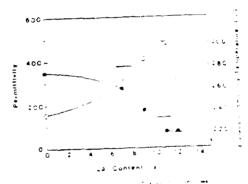


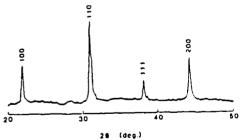


Rf-planar Magnetron Sputtering System

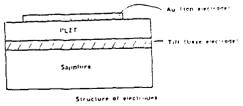
TABLE 1. Sputtering conditions.

Target	PLZT powder, 1004
Substrate	Sapphire
Substrate temperature	500~700 °C
Sputtering gas	Ar(60%)+0,(40%)
Gas pressure	6,3x10 ** Torr
Rf power	160 W
Deposition rate	70~100 A/min
- •	



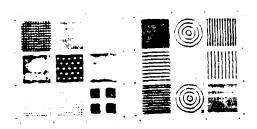


E-ray diffraction potterly of PLET(1/65/35) thin like

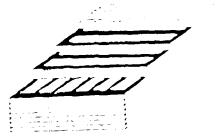


PHERARATION OF CEHAMICS WITH CHUERED VOIL ARRAYS

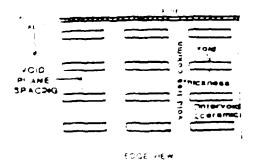




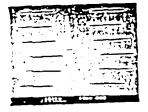
VOIDPATTERNS FOR DEPOSITION OF FUGITIVE INK



SCHEMATIC OF CERAMIC WITH CROSSED BAR SHAPED VOIDS MADE BY RUTATING PARALLEL BAR PATTERN BY BU IN ALTERNATE LAYERS



MODEL OF CERAMIC WITH SQUARE SHAPED VOIDS



CROSSECTION OF CERAMIC WITH CORNER CONNECTED SQUARE SHAPED VOICS

VOID THICKNESS 0 54 x 10-3 in VOID PLANE SPACING 3.7 x 10-3 in.

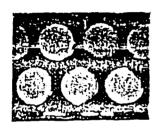


TOP VIEW OF CERAMIC HAVING CORNER CONNECTED SQUARE SHAPED VOIDS VOID LENGTH AND WIDTH 11.5 ± 10-3 in.



TOP VIEW OF CERAMIC HAVING UNCONNECTED SOURCE SHAPED VOIDS

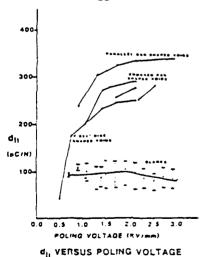
VOID LENGTH AND WIDTH 28 x 10-3 in.

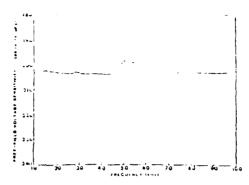


TOP VIEW OF CERAMIC HAVING DISC SHAPED VOIDS

VOID DIAMETER 24 x 10-3 in.

OPTIMUM POLING VOLTAGE IS 2.1 KV/mmL AVERAGE d₃₃ IS 353 pC/N.





FREE FIELD OPEN CIRCUIT VOLTAGE SENSITIVITY OF

INFVICE SENSITIVITY LESS 4 208 OF CABLE ATTENUATION IS SHOWING

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THE CROSSED BAR PATTERNHAS THE HIGHEST PIEZOELECTRIC SENSITIVITY

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SAMPLES EXHIBIT NO IRREVERSIBLE PROPERTY CHANGES UP TO AT LEAST 1000 psi.

RESONANCE MEASURING TECHNIQUE FOR COMPLEX

COEFFICIENTS OF PIEZOELE CTRIC COMPOSITES.

ΒY

QICIXU, AIR RAMACHANDRAN AND RIE NEWNHAM

MATERIALS RESEARCH LABORATORY, THE PENNSYLVANIA STATE UNIVERSITY, UNIVERSITY PARK, PA 16802.

INTECOLICTION

Two measurement techniques for prezoelectric composites based on resonance methods are described. One is used for estimating the real coefficients and is based on a tumped equivalent circuit model. The other involves the complex coefficients derived from an analytical solution of a single mode vibration. Representative piots of conductance-vs-frequency, capacitance-vs-frequency and the mechanical quality factor, Q_m are presented along with the real and imaginary parts of the dielectric, elastic and piezoelectric coefficients of 0-3 composites(NTK), 0.3 fired composites(PZT), Lead titanate-Bismuth ferrite composites, PVDF voided thick films and PVDF nonvoided thin films.

Resonance Technique for Messyrine the Complex Coefficients of Pieroelectric Composites

TE (Thickness Mode)

$$c_{33}^{0*} + c_{33}^{0}(1 + jj) , j = can + m$$

(Assume $D^2/J^2/(PH)^2 \leftrightarrow 1.5$

The impedance of the thickness mode is

$$z = \frac{1}{2vC_0^2}(1 - \frac{r_1^2 \cosh b^2}{b^2})$$

where

$$8^{\circ} + \frac{\sqrt{2}}{2V^{\circ}} + \frac{\sqrt{2}}{2V}(1 + V_{2}^{2})$$

1f p 1 pm . n 4 then error <u>(0.1-</u>

4 2 - 4 114 1 2845

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$$\theta = \frac{1}{2 \cdot 6} \cdot \left(2 + \frac{4 \cdot 2}{6} \cdot \frac{(\tan \frac{15}{2} \cdot 4) + (\sin^2 2 \cdot 4) + (0 + \frac{1}{4} + 2) \pi (\tan 2 \cdot 4 + \sin 2)}{(1 + \tan 2 \cdot 4 + \sin 2 \cdot 4)} \right)$$

$$x = \frac{1}{\sqrt{a}} \left(-1 + \frac{\sqrt{2} \left(\tan \theta \right) + \tanh \left(\frac{1}{2} + a \right) + \left(a + \frac{1}{2} + 1 + \tanh \left(\frac{1}{2} + \frac{1}{2} \right) \right)}{\left(1 + \tanh \left(\frac{1}{2} + \frac{1}{2} \right) \right)} \right)$$

$$\frac{1}{\sqrt{2}} = \frac{1}{\sqrt{2}} \left(\frac{1}{\sqrt{2}} + \frac{1}{\sqrt{2}} + \frac{1}{\sqrt{2}} + \frac{1}{\sqrt{2}} + \frac{1}{\sqrt{2}} + \frac{1}{\sqrt{2$$

Therefore.

$$\frac{c_1 + c_2}{c_2} + c_3 + c_4 + \frac{c_4 + 5c_4}{c_2}$$

una-a

$$\mathbf{U}_{2} = \operatorname{can} b_{2}(1 + \operatorname{cann}^{2} \frac{b_{1}(1)}{2})$$

$$\mathbf{A}_{\underline{k}} = \mathbf{b}_{\underline{k}} \cdot \mathbf{k} + \mathbf{can}^2 \mathbf{b}_{\underline{k}} \cdot \mathbf{cann}^2 \cdot \frac{\mathbf{b} \cdot \mathbf{J}}{\frac{1}{2}}$$

$$Q_L = cann \cdot \frac{b \cdot T}{T} \cdot (1 + can^2 s_L)$$

$$B = D + \frac{J}{2} + 2PH$$

$$t=1,\ 2,\ 3$$
 (corresponding to f_1 , f_2 and f_3

Using an iterative method, the values of κ_{\perp} PM and 1 are calculated

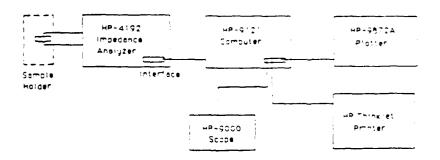
Further

$$h_{33}^{\bullet} = k_{1} \frac{\overline{c_{33}^{\bullet}}}{\overline{c_{33}^{\bullet}}} (1 + j_{1} PH + \frac{1}{2} J + \frac{1}{2} G_{1})$$

$$\bullet_{33}^{\bullet} = k_{2} \frac{\overline{c_{33}^{\bullet}}}{\overline{c_{33}^{\bullet}} c_{33}^{\bullet}} (1 + j_{1} PH + \frac{1}{2} J + \frac{1}{2} G_{1})$$

$$v^{\bullet} = vc_{1} + j\frac{1}{2} J$$

A similar procedure was followed for the other modes



SCHEMATIC DIAGRAM OF THE MEASURING TECHNIQUE

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 $\begin{aligned} & s_{1} + s_{22} + s_{33} \\ & s_{3}^{2} + s_{33}^{2} + s_{33}^{2} + s_{32}^{2} + s_{33}^{2} \\ & s_{6} + s_{6}^{2} + s_{63}^{2} + s_{63}^{2} \end{aligned}$

 $P = \frac{2 \cdot 1 \cdot 4 \cdot 1}{R_1 \cdot 1 \cdot 1 \cdot 1 \cdot 1}$ $P_1 = 2 \cdot 1 \cdot 1 \cdot 1 \cdot 1$ $P_2 = \frac{P_1 \cdot 1 \cdot 1 \cdot P_1}{R_2 \cdot 1 \cdot 1}$

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Table 1 Property Coarr events Measured tong to tell the

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Complex election	E 1410 - 1+v 1631 - (fri 1348)	13 0:10 0 (** 23) ** ** ** ** ** ** ** **	1 1830	1 00010 010 204 . 10 1020 04 .	•
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Density (Eg/m ³)	4 23 : 102	4 796103	1,3:103	1 46:103	1 78×10 ³
Compliance is 2/8)					
s [£] 11	3 64x10 - 1 D	0 76:10-10	9 22410 -10	3.71×10-10	- 10 1 Pajo (1-0 11)
5 ^E 11	1.64210-10	0.19x10-10	2 67830-10		. (1-0-1)

. Voided uni-streamed thick file 2Non-voided bi-streened thin file

*Varies obviously with frequency

SUMMARY

- 1) Regarding the complex opendients the nexaliterent from dies are enective even for samples with $C_{\rm ack}$ and a squalot ment $M_{\rm ack} M_{\rm ack} \sim 0.0$ When Q₂ > 10 and X²Q₂20 CDS the measuring rechnique for real coemcients — 3 solid. The energye electromechanical coupling speric entitles can still be abowed for estimating approximate magnitudes.
- 2) The experimental results indicate that the diezoelectric calend enting is complex, violating the usual assumption that his real
- 3) Using just one disk composite sample, it is cossible to estimate all of the real coefficients for the LE. _ TE PE and Hydrostauc modes
- 4) Eccause experimental data for (C.C.), Clare very acquirate life error in the coefficients can be reduced to less than 5% when the vibration mode is
- 5) For the Hersaye method, we recommend chalces for the three measurement "reduencies which lead to radio convenience

5. The rechnique for measuring rhai coefficients can be applied to single made viorations of law Q _ ransqueers viorating in a liquid or attached to conversion efficiently and the bandwidth can be esumated in this manner

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- In principle, these lechniques can be used for measuring the broberty coefficients as a function of frequency if the sample size is changed
- 3) These rectiniques are not suitable for high C_{∞} dietoelectric determics but are useful for measuring composites and PMCR I im properties

FERROELECTRIC COMPOSITE

TRANSDUCERS

B A AULD

DEPARTMENT OF APPLIED PHYSICS

STANFORD UNIVERSITY

STANFORD, CALIFORNIA 94305

PROPERTIES

Low Acoustic Impedance

Strong Electromechanical Coupling

Reasonably Large Dielectric Constant

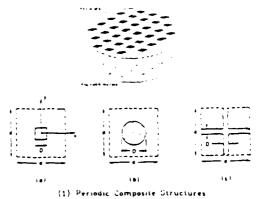
Low Electrical and Mechanical Losses

Reduction in Image Transfer Crosstalk

Elimination of Interfering Lateral Modes

DESIGN RULES

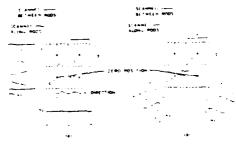
- If To entimate the operational characteristics it is necessary
 to select a volume traction of the piezonectric phase that
 trades oil low imposance versus strong electromechanical
 coupling and large dielectric constant.
- .III The 2n stephand egge modes which couple to the electrodes, can berievally reduce the coupling to the fundamental thickness resonance mode. This can be avoided by choosing the composite period to be small compared with the transducer thickness, but this variation also affects the volume fraction parameter, and
- when the in stophand is chosen to satisfy (II), it is stimpossible to place the thickness resonance inside the nistophand. This is important occause it prevents lateral propagation at the excitation from new-the cause of mechanical crossials—and also eliminates lateral resonances of the transducer at and near the thickness resonance of the transducer. These latter mades sectiously influence the character of the desired thickness resonance and complicate the design of low frequency transducers.



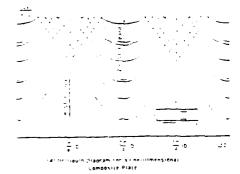


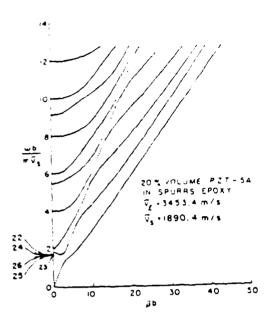


SE GEO 100 200 2500 FREQUENCY (SHE)

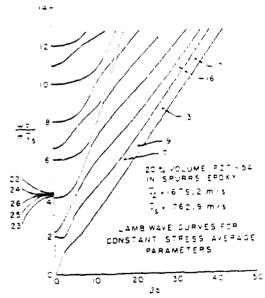


(2) Standing wave valverns at the castice tage (a) and cattice Diagonal (b) 2n Standands

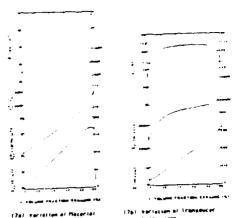




(5) Constant Strain Modeling of a One-Dimensional Composite Plate: Thickness Resonance is Accurately Predicted



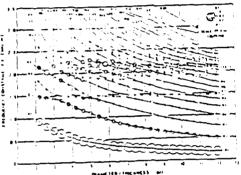
(6) Constant Stress Modeling of a One-Dimensional Composite Plate. Stoppand Reconances are Accurately Predicted



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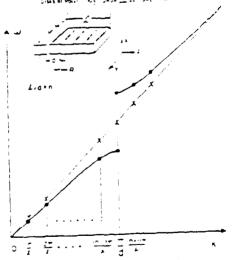
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tingm or a. Smith or pt. "Tailoring the Properties of Composite
PrezenedUnic Materials for Projects Ultrasonic Transactors,"
1965 (EEE Ultrasonic Symposium)



CBI Caterial and Thickness made interactions in a honcombosite Disa Transducer.

Tron 5 Uses C Sauma and C more Theasterment of interaction engine distributions and more enables of Thick Disas of Object 1005 JANA 2000 3-21-44-21.



* * * Proceedings to Resonator Lateral modes
 * * Composite Resonator Lateral modes
 * * Induced in the Lateral model Spectrum by the in mode Stoopand of a Une-Cimensional Composite

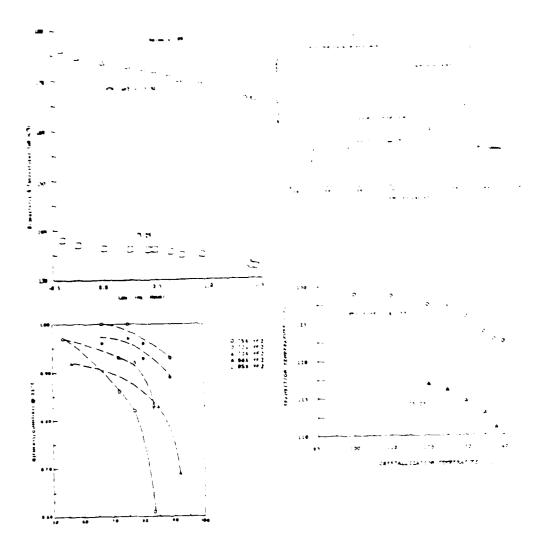
PIEZOELECTRIC PROPERTIES OF SOME NEW HYDROPHONE MATERIA'S

Robert Y. Ting

Underwater Sound Reference Detachment U. S. Naval Research Laboratory Orlando, FL 32856-8337, U.S.A.

New piezoelectric materials are constantly sought for sonar transducer applications in order to improve performance and reliability. We have a continuing effort in this endeavor under the support of the Office of Naval Research. Recent interest has been in the materials for large-area hydrophones. Polyvinylidens fluoride is now known to be inadequate as a large-area hydrophone material because of its poor thermal stability, low dislectric constant and planar anisotropy. Alternative materials are therefore being sought in the research program at the Underwater Sound Reference Detachment, Naval Research Laboratory (MRL-USRD). Recent studies have been concentrated on three material systems:

- Pieroelectric copolymers of vinylidene fluoride and trifluoroethylene,
- (2) A "1-3" type piezoceramic composite developed by Plessey Australia Ltd., and
- (3) New lead titanate ceramics available from both Japanese and U. S. sources.
- (1) Temperature Effects in VDF/TrFE Copolymers
- * High remperature exposure leads to greater losses in sample's piezoelectric activity if VDF content is lower.
- * The degradation is related to a solid-state transition characterized by changing from a well ordered, ferroelectric, all-truns configuration to a paraelectric phase of disordered pseudohemagonal lattice structure in the crystalline region.
- * This transition is found to be affected by both thermal treatment and the crystallization temperature the sample was emposed to, as evidenced by differential scanning calorimetry (DSC) results. Further wide-angle X-ray investigations are being carried out to further characteize the crystalline phase.



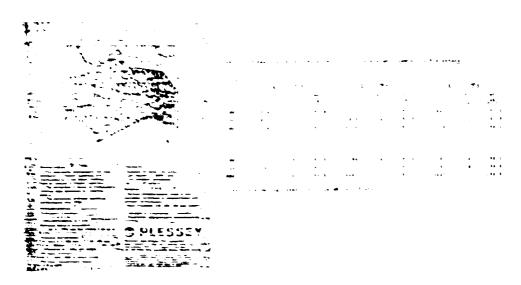
(2) Plesser Australia "1-3" Payzopacamia Jamposaca

Reference: M. Baker and I. Bakerell. "Acoustical Sepsitivity of PCT Polymer Composites As A Function of Fabricating Parameters", Presented at the Amer. Cera la Soc. Mat., Pittsburg, PA April 1984.

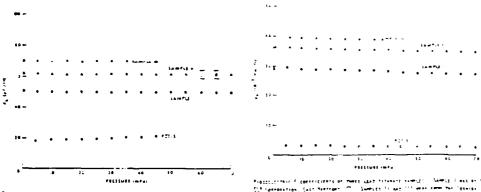
Samples evaluated are described in the manufacturer publication as shown below. The complete specifications are given. The samples were tested for their capacitance, dissipation and sensitivity as functions of pressure, temperature and frequency. Data are tabulated as shown in Table I.

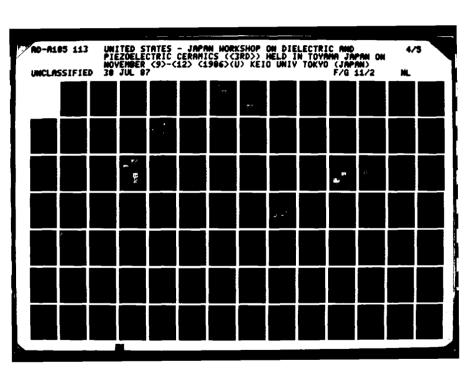
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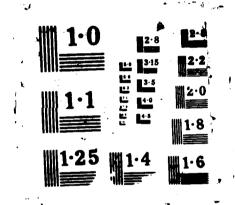
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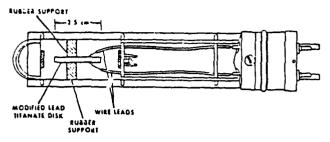
The prescelectric grand a conformation of new lead titungte sammiks which en alguits un in alle table mode as a function of product of Tokyainun dinordent properties ward invistigates in two stunders TIRE transqueer houseness, covering the rules of 1-100 kdz and 200 kdz-2 Miz. Thus hew seramic mate hal is attractive because of its highdielintric constant, good mechanical strength, low planar coupling and high thickness coupling.







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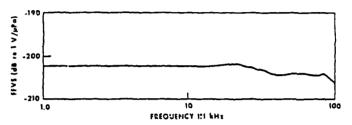
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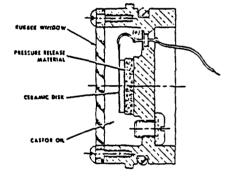
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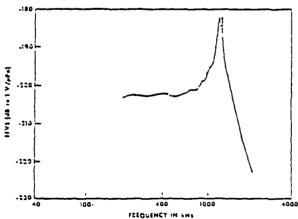
CONTRACTOR OF THE STANDARD STANDARD FOR THE STANDARD STAN

SECTIONAL VIEW OF THE ISSPETIVE MET STANDARD HYDROPHONE HOUSING, USER FOR LON-FREDUENCY EVALUATION OF LEAD TITANATE CERAMICS.



FREE FIELD VOLTAGE SENSITIVITY OF LEAD TITANATE SAMPLE IN MES HYDROPHONE.





FREE FIELD VOLTAGE SENSITIVITY OF LEAD TITANATE CENAMIC CAPPLE IN ES YRANSDUCER.

DIELECTRIC AND PIEZOELFCTRIC PROPERTIES OF PEZOG-PU(Zn1/3Nb2/3)04 CERAMCS

K. SAKATA and T. TAKENAKA

Faculty of Science and Technology, Science University of Tokyo, Koda-shi, 278

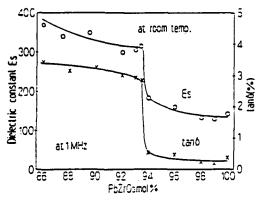
Introduction

Lead zirconate PbZrO₂ is a typical example of an antiferroelectric, and has been the most widely studied of the antiferroelectrics. Its solid solution system with PbTiO₂ (namely, PZT) has been investigated in detail, because the PZT system has a morphotropic phase boundary (MPB) whose components give superior piezoelectric activity.

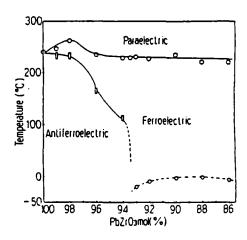
Application of an electric field to PbZrO, can induce a ferroelectric phase in the puckered structure in a certain temperature range, because the free energy of the puckered structure of PbZrO, seems to be very close to that of the ferroelectric phase.

Small additions of Ba or Ti to PbZrO₂ remarkably lower the free energy of the ferroelectric phase. For example, if 5% of the Pb ions are substituted by Ba, or about 1% of the Zr ions by Ti, a ferroelectric phase shows up even if no dc field is applied. Extensive research of PbZrO₂-based compounds has been made from the standpoint of phase transitions. Recently, Takeuchi et al. found a large anisotropy in the electromechanical coupling factor of one PbZrO₂-based ceramic.

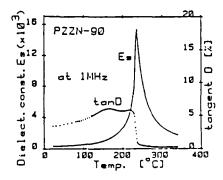
In this work, we have attempted to obtain basic information regarding a new piezoceramic group, from an applicational viewpoint of electronic device material. The dielectric, piezoelectric and pyroelectric properties of the PbZr_x(Zn₁₀Nb₂₀)_{1-x}O₃ solid solution (abbreviated to "PZZN-100x") with up to 20 mol % (Zn₁₀Nb₂₀) were investigated.



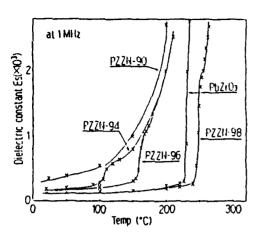
Dielectric constant ϵ_s and loss tangent $\tan\delta$ at room temperature of the PZZN system as a function of PbZrOs mol %(x).



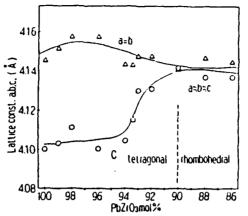
The phase relation of the $PbZr_a(Zn_{ex}Nb_{ex})_{z=2}O_a(PZZN)$ system.



Temperature dependence of dielectric constant ϵ_z and loss tangent $\tan \delta$ of PZZN-90 (x=0.9).



Temperature dependence of dielectric constant ϵ_s of the PbZr_s(Zn₁₁₈Nb₁₁₈)_{1-e}O_s(PZZN) system.



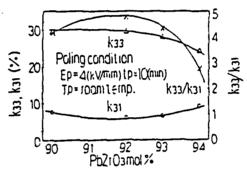
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Unit cell parameters of the PbZr₄(Zn₁₁₃Nb₁₁₄)₁₋₄O₄(PZZN) system.



Coupling factor as and assemble ratio audass of the

Piezoelectric properties of the PZZN-90 and PZZN-92.

	Cleiectric-	Loss lang	Coupling factor	Frequency const.	Elastic compilance	Piezoeiectric constant
	රාග් රාදි	(अध्यक्षा	kaa kai kii ko kis	Naa Nai Nt No Nis	Sif Sif Sif Sif Sif Sif Sif	daa dar dis 9aa 9ar 9is
	10kHz	(%)	(%)	(Hz·m)		(เอ๋เร็ตพ) (พระพา)
FZZN-SC	300 385	203 279	79: 133 603 841 535	2040 2710 1520	723 198 740 14.1	1427 139 <u>159</u> 1 862 16.1 40.5
PZZN-92	262 386	Z49 150	252 420 157 m3 157	2090 2390 1560 2050 2760	7.73 205 745 815 7.70 133	402 157 349 EC9 173 455

Piezoelectric Properties of (Na,Li)NbO₃ Ceramics

T.HONDA
I.KAWAMATA
H.WATARAI
T.IDO

Materials and Electronic Dvice Laboratory,

Mitsubishi Electric Corporation

Sagamihara-city Miyashimo 1-1-57, Kanagawa 229, Japan

The PZT family of ceramics is currently being used in most applications utilizing piezoelectric polycrystalline materials. For the application transducers for non-destructive testing, PZT ceramics present technological difficulties.

New materials with

- (1) higher frequency constant.
- (2) lower dielectric constant are required

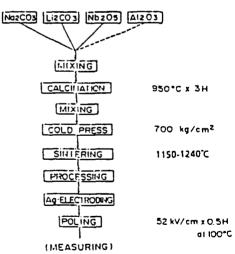
 $(Na,Li)NbO_3$ family of ceramics is one of the desirable materials.

The purpose of this work is;

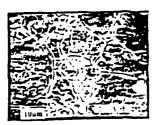
- (1) to improve the siterability of (Na,Li)NbO₃ ceramics , and
- (2) to measure the piezoelectric properties for the high-frequency ultrasonic transducers.

Experimental

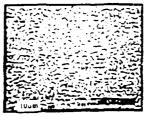
1. Sample preparation



- 2. Measurments
- (1) Microstructures
 Density, SEM, XMA
- (2) Piezoelectric and dielectric properties
 Coupling factor, Dielectric constant (3)



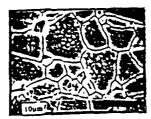
non additives



0.5 wt. % Al2O3

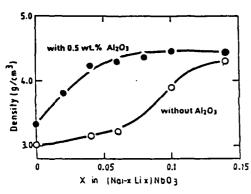


0.5 wt.% MgO

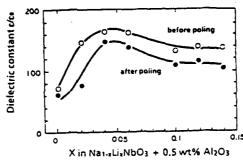


n s we % MnC

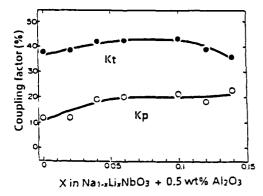
SEM photographs of the Na_{0.9}Li_{0.1}NbO₃ systems with additives. (1180°C x 3 hrs)



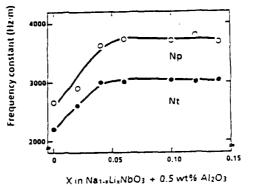
Densities of Na_{3-s}Li₄NbO₃ systems as a function of lithium concentration.



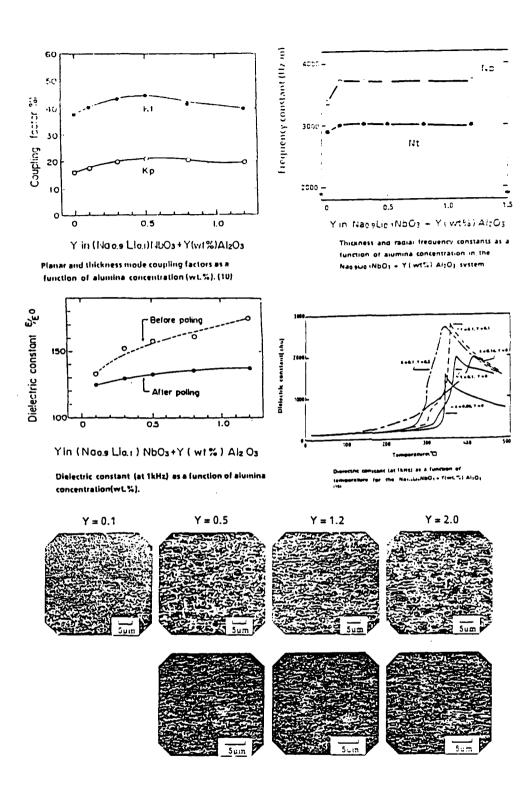
Dielectric constant (before and after poling) as a function of lithium concentration in the Nat...Li.NbO₃ + 0.5 wt% Al₂O₃ system.



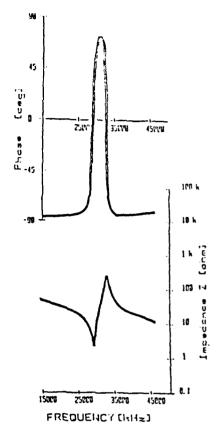
Thickness and planar mode coupling factors as a function of Ilthium concentration in the Na_{1-x}Li_xNbO₂ + 0.5wt% Al₂O₂ system. (7)



Thickness and radial frequency constants as a function of lithium concentration in the Nat-«Li-NbO3 + 0.5 wt% Al₂O₃ system



SEM micrographs (upper) and Al-Ko X-ray image (lower) of Na_{0.9}Li_{0.1}NbO₃ + Y(wt.%) Al₂O₃,



Thickness-mode resonance of NaggLig.18bO3 + 0.5wt.% AlzO3 for vibrating element. (17)

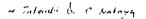
Summary

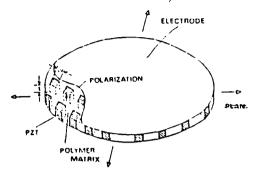
Sodium-Litium niobate systems have higher frequency constant and lower dielectric constant than those known for PZT piezoelectric ceramics.

In order to improve the sinterability of the sodiumlithium niobate systems, the effect of alumina addition has been investigated.

It was found that alumina addition enhanced the density of the sintered body and improved the microstructe and piezoelectric properties for the sodium-lithium nìobate system.

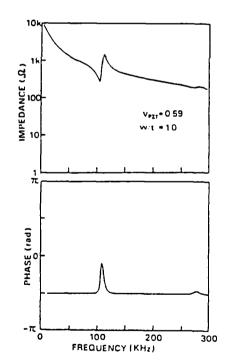
(Na,Li)NbO₃ with a small amount of alumina is desirable material for the fablication of high frequency ultrasonic transducers for non-destructive testing.



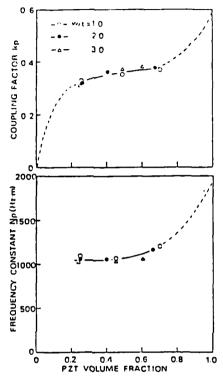


STRUCTURE PARAMETER : PZT VOLUME FRACTION VIEW

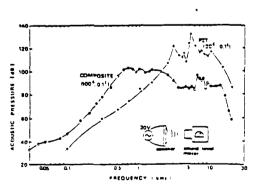
PIEZOELECTRIC COMPOSITE DISK VIBRATOR



IMPEDANCE AND PHASE CHARACTERISTICS OF PZT/EPOXY COMPOSITE DISK (diameter::11mm thickness:04mm)



FREQUENCY CONSTANT AND ELECTROMECHAN-ICAL COUPLING FACTOR OF PLANAR VIBRATIONAL MODE IN COMPOSITE DISK AS A FUNCTION OF PZT VOLUME FRACTION (Sample thickness:01mm)



PREQUENCY CHARACTERISTICS OF PIETOELECTRIC SPEAKER

Anisotropic Piezoelectric Coupling Factor of [Pbx(Bio., Nao.,) 1-x] TiO, Ceramics

S.Tashiro, Y.Oikawa, H.Igarashi and K.Okazaki The National Defense Academy

- 1. Dielectric and Piezoelectric Properties of PbTiO₂ ~ (Bi_{0.5} Na_{0.5}) TiO₃ system.
- 2. Effect of third components on piezoelectric coupling factor in PbTiO₃ (Bi_{0.5}Na_{0.5})TiO₃ -Pb (B1·B2)O₃ system.

(Bia., Nao.,) TiO, ceramics

By Smolenskii et al of USSR in 1960

Crystal structure : Perovskite

Rhombohedral

Curie Temp. : 320° C Ferroelectric

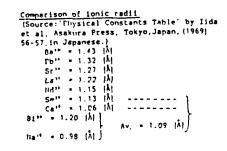
x. PbTiO, -y. (Bio., Nao.,)TiO, system By Sakata et al of Japan in 1967 M.P.B. : x = 12.5 mol kp = 0.28 and Pr = 33 [μ c/cm²] at H.P.B. No Piezoelectric data in the tetragonal region with large c/a.

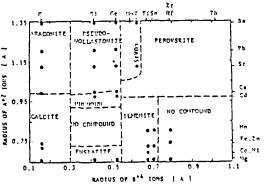
Substituting elements of A-site in PbTiO, ceramics

La : Matsushita Ba,Sr,Ca : Toshiba La,Pr,Nd,Sm,Gd : Hitachi

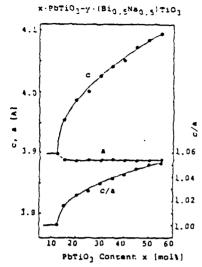
Ca and Sm→ Large piezoelectric Anisotropy

Ionic radius of Ca or Sm is smaller compared with Pb, Ba, Sr and La ions.

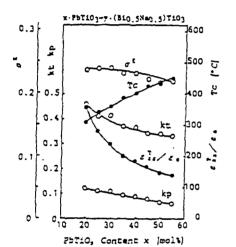




Classification of the A*25*403-type enapounds according to constituent ionic radii. From R.S.Poth, Journal of Research of The National Bureaus of Standards, vol.38,No7 (1937)



Lattice parameters of the x-PbTiO3-y-(BiO.5NaO.5)TiO3 system as a function of PhTLO3 content (x).

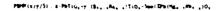


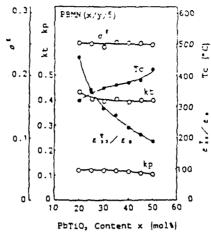
Electromechanical coupling factors kp,kt,dielectric constant $\varepsilon_{23}^{2}/\varepsilon_{0}$, Curie point Tc and Poisson's racio σ^{ξ} of the x-PbTiO3-y-(BiO,5NaO,5)TiO3 ceramics. constant $\varepsilon^{\frac{1}{13}/\varepsilon_0}$. Curie point Tc and Poisson's racio σ^{ξ}

Sinterability of the ternary system x.PbTiO, -y. (Bi.., Na..,) TiO, -z.Pb (B | B])O,

BI and BI were restricted to the elements with radii nearly equal to that of Ti

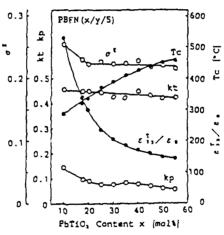
2-component		Sinterability
5mol%	Pb (CoW) O,	×
*	Pb (CrNb) O,	Δ
~	Pb (FeNb) O,	ō
<i>*</i>	Pb (MgNb) O,	ŏ
*	Pb (MgW) O,	×
~	Pb (FeW) O,	×





Electromechanical coupling factors kp,kt, dielectric constant g 1/co, Curie point Tc and Poisson's ratio ot of PBMM(x/y/S) as a function of PbTiO1 content (x).

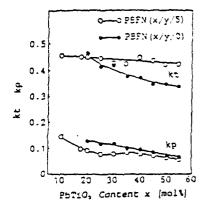
PSFH(a/y/5): x-PbYiO,-y-(Bi,-,Na,-,)YiO,-SmilZPh(Fa,-,db,-,)O,



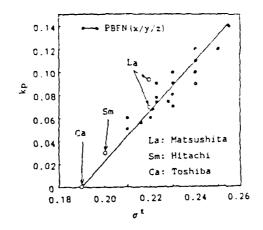
Electromechanical coupling factors kp,kt, dielectric of PBFH(x/y/5) as a function of P5TiO₃ content (x).

Dielectric, Fieroelectric and Elestic constants of 0.5-PbTiO₁-0.65-(Bio.,Na.,)TiO.-0.05-Pb(Fe.,,Nb.,,)O, ceramics with 1 mol4 MMCO₁. (PBFN30/85/5)

Dielectric consta		Frequency constan	12
zin/se fat 1 k	Hz) : 203	Np (Hz - m)	: 2296
2.11	1 191	н	2 2157
Coupling factor		N.,	: 1915
kp .	1 0.577	N:	2242
X.	: 0.050	N.,	1 1469
kt	: 0.457	Elastic compliance	
t.,	: 0.625	# . (10" " #1/N)	1 10.4
¥.,,	: 0.764	1.	: -2.4
Pigioelectric con	stant	a	1 -1.5
4. (10 '* =/V)	- 6 B	s{,	1 8.5
4,,	52.5	41.	119.0
d	4.17.4	Mechanical qualit	y factor
q., (10 ' V m/N)	: - 3,8	Om	: 1100
411	: 29,1	Poisson s ratio	
9.4	c 27.9	a == a = /a = .	: 0.727
Density		Curie point	
p (9/cm*)	1.6.57	te (T)	: 390



Effect of substitution of 5 mol2 Pb(Fe $_{0.5}$ Nb $_{0.5}$)0 $_{\rm J}$ on coupling f. ctors kp,kt of PBFN(x/y/0).



<u>,</u>

A CHARLES THE TWO DOES NOT THE PROPERTY OF THE PARTY OF T

Correlation between Poisson's ratio σ^f and coupling factor kp in PbTiO3 ceramics modified with various substituting elements.

Summary

Dielectric and piezoelectric properties of the x PbTiO, -y (Bio., Nao.,) TiO, -z Pb(B | B |)O, system with 1 mol% MnCO, were experimentally investigated.

- 1) In the x PbTiO₁-y (Bi_{0.5}Na_{0.5})O₃ system, the dielectric constant was smaller than 200 and the Curie point Tc was higher than 380 $^{\circ}$ C in the compositions above x = 0.25.
- 2) Substituting with 5 mol% Pb(Fe_{0.5}Nb_{0.3})O₃ was available in enhancement of the piezoelectric anisotropy, Kp = 0.077 and kt = 0.457 were obtained in PBFN(30/65/5).
- 3) More improvement of the properties such as small dielectric constant, high Curie point and large piezoelectric anisotropy can be expected by adjusting amount of Pb(Fe_{0.5}Nb_{0.5})O₃ and MnCO₃ additive.

HISAO BANNO

NTK Ceramic Div. NGK Sparkplug, Japan

Effects of Shape and Volume Fraction of Closed Pores

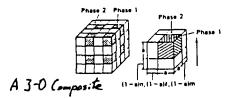
on

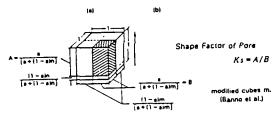
Dielectric Loss Tangent, Mechanical Quality
Factor and Electromechanical Coupling Factor

of

Dielectric and Piezoelectric Ceramics

- A Theoretical Approach -





2nd US-Japan Seminar(1984) at Williamsburg

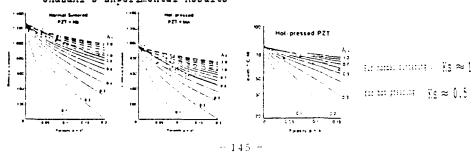
Theoretical Equations based on modified cubes model:

$${}^{1}X/X_{0}(\overline{\xi_{23}^{*}}) = 1 + \frac{1}{p^{1/2}({}^{1}\xi_{23}^{*}/\xi_{0} - 1) + 1} \cdot \left(\frac{p}{Ks}\right)^{2n} + \left(\frac{p}{Ks}\right)^{2n} \tag{1}$$

$${}^{3}X/X_{s}(\overline{d}_{21}) = 1 - \left(\frac{p}{Ks}\right)^{1/2} + \frac{\left(\frac{p}{Ks}\right)^{-1} \left(1 - \left(\frac{p}{Ks}\right)^{-1}\right)}{1 - p^{-2} \cdot Ks^{-2}}$$
(2)

$${}^{3}X/X_{\bullet}(\overline{E}1_{1}=1/\overline{g}1_{1})=1$$
 $-p^{2/2}\cdot K_{g}^{-/2}$ (3.)

Okazaki's Experimental Results



A:	ssuming that	
^	'E., = 0	(44)
	'en = 0	(45)
Ψ	'E 12/E0 = 1	(46)
	and 'tan 812 = 0 .	(47)

	$Q_{m,i} = 1/I_{4ij} \delta_{mij} = 1/2 I_{2ij} \delta_{mij} = 2Q_{mij}$	(48)
- (ian 8 1 = 1/Q11 = 2tan 311 = 1/2 Q11	(49)

PZT+Mn (Okazaki at al.

PZT+Mn(OkosakioTal)

Id-prosed PET

(Okazaki et al.)

0.25 0.25 0.20

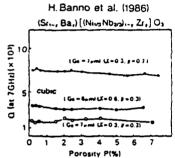
0 10 0.05

Electromechanical Coupling Factor kg

$\overline{g}_{12} = g_{12} (1 - P''' \cdot K_S''')$. Resonant impedance Zr

$k_s^2 = \frac{2d\beta_s}{C_{2s}^2 \cdot s \cdot f_s(1 - s \cdot f_s)}$	1501
$tan \delta_{-1} = 2\pi f_{\pi} \cdot C \cdot Z_{\pi} (1 - (f_{\pi}/f_{\alpha})^{2})$	(51)
/r = 1// pil - (01)2) - 11.	1521
$C = \epsilon_{32}^{\prime}$	(53)
1/46=0 395(/,//a)/(1-(/,//a))+0 575	(54)
$\overline{\rho} = {}^{1}\rho(1-a^{2}) = {}^{1}\rho(1-P)$	(55)

$\therefore \overline{kp} = f(P, K_p)$	(56)
To SIR EL	



Shape Factor of Pore Ks

	₹,,	J,	1/51.	71,	T,	7,
Normal Sintered TiOs	Ks=1					
Normal Sintered PZT + Nb	Ax= 1		Ks=1			
Hat-Pressed PZT + Mn	Ks=0.5	hs=0.5	hs=0.5	As=05	/\s=0.5	h,=0 5
Hot-Pressed PLZT		Ks=0.5			(As=0 5)	(A's ≈ 0.5)
(Sr. Dal((Nico		• 00	porosit	depend	sence of	Qm
Nhaal. Zr)Us		no po	orosity d	epender	ce of Q	

Conclusion

- 1. Theoretical equations for dielectric (ε , $tan \delta$), elastic (s, e, Qm) and electro-mechanical (d, k) properties : a function of shape factor (Ks) and porosity (P)
- 2. This theory is applied to the experimental resuets obtained by Okazaki et al. with good agreement between theory and experiments.
- 3. \mathcal{E}_{32}^{T} , \mathcal{S}_{11}^{T} , \mathcal{S}_{12}^{T} , \mathcal{S}_{22}^{T} , \mathcal{S}_{32}^{T} , and kp: dependent on not only volume fraction but also shape and distribution of pores, whereas Qm and $Ql = 1/tan \delta$): of no porasity dependence
- 4. This theory predicts no effect of size of pores on the above-mentioned properties.

W10

EFFICIENCY OF PIEZOELECTRIC CERAMIC ACTUATOR

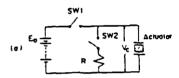
Sadayuki TAKAHASHI NEC Corp.

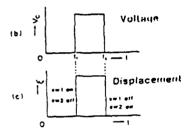
Introduction

in order to operate the piezoelectric ceramic actuator in a pulse mode, a charge discharge circuit is required. A conventional circuit, however, wastes unused alored energy in the actuator in every discharge cycle

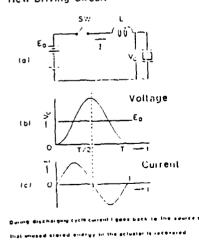
The present study reports a new driving circuit

Conventional Driving Circuit

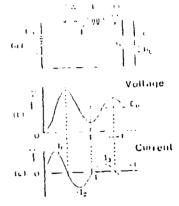




Hew Driving Circuit



Actual Equivalent Circuit



in the actual case a part of energy is tost as heaf the recured

energy is less than the supplied every:

For W=0
$$E_{S} = E_{0} \int_{0}^{\tau/2} 1 dt$$

$$E_{T} = E_{0} \int_{\tau/2}^{\tau} 1 I I dt$$

$$L_{1} = \int_{0}^{\tau/2} (R_{L} + R_{C}) I^{2} dt$$

$$L_{2} = \int_{\tau/2}^{\tau} (R_{L} + R_{C}) I^{2} dt$$

$$M_{SI} = k^{2} E_{S}$$

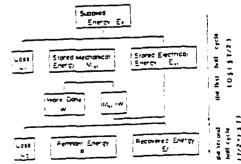
$$k^{2} : coupling const.$$

$$E_{SI} = E_{S} - (M_{SI} + L_{I})$$

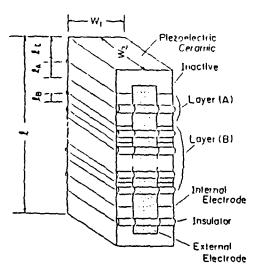
$$R = \{E_{SI} + (M_{SI} - W)\} - (E_{T} + L_{2})$$

$$R_{L} + R_{C} = \frac{2L}{T} \log_{C} \frac{l_{1}}{l_{3}}$$

Energy Flow Chart



Specimen

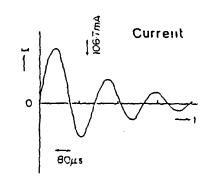


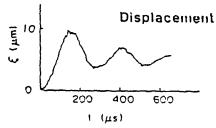
 $1xW_1xW_2:9x2x3mm$

1: 0.59 (2 loyers)
1: 0.23 (4 ·)

18: 0.115159 ·)

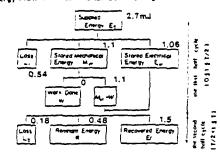
Experimental Results





E:787, L:10mH,R,:10Ω

Energy Flow without Mechanical Loading



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SS 1888

ā)

12

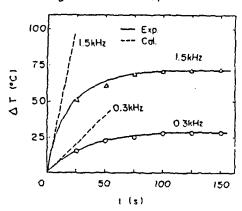
67

22

250 CS

(ESSASSO PROPOSODO BOS SOS SOS

Actuator Temperature Rise during Pulse Mode Operation



Summary

For pulse mode operation without mechanical loading, 56 percent of the supplied energy can be recovered using a new circuit.

21 percent of the supplied energy is lost as heat in the actuator.

W11

CERAMIC GREEN SHEET PUNCHER
USING PIEZOELECTRIC ACTUATOR
Tadashi YOSHIURA
NEC Corp.

Introduction

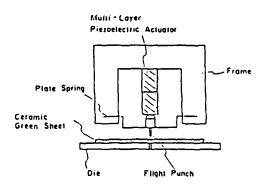
Multilayer ceramic wiring substrates which are used for high-speed large computers, are usually produced by ceramic green sheef fechnologies.

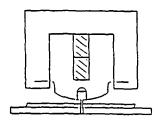
Individual ceramic green sheets used here have many liny via holes to achieve a three dimensional wiring.

This report deals with a high precision and high speed green sheet puncher for via holes.

The puncher is basically driven by piezoelectric ceramic actualors.

Basic Structure





Punching by Flight Punch

Punch Flying Length

አንግር እና መጀመር ነው መመን በተመመው በመደር የሚያስከት የሚ የመመር የሚያስከት የሚያስከት

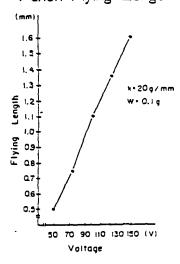






V: Valtage Impressed on Plezaelectric Actuator

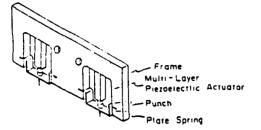
Punch Flying Length



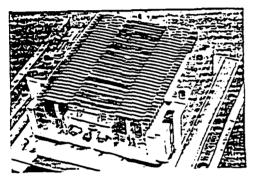
k: Spring Constant

W: Punch Weight

Punch is fastened to plate spring

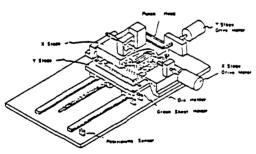


Punch Head Structure

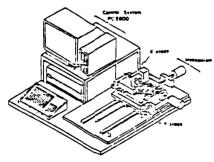


Punch Head has 60 punche

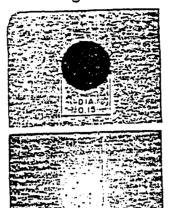
Mechanism



Punch System



Through Hole



Punch System



Punch System Specifications

-discir bystom	
y V Stoor	4 2 mm / 100
***	60 Pins tel 2 Innesi
Figure Lampid	1 mm 1 e1 120 YI
Place Spring Response Frementy	((rem resource)
Termon Hote Chamerer	# 0 13 mm
Corough Hotel Piece	1 293 mm
Income man Price Every	1 0 03 mm
Tarauga Mala Munaari	About 2400/Sheet
Ports Abelley	90 set / 2400 Males
Cross States Chargeston	100 μm
Green Sector State	100 mm × 100 mm

Conclusion

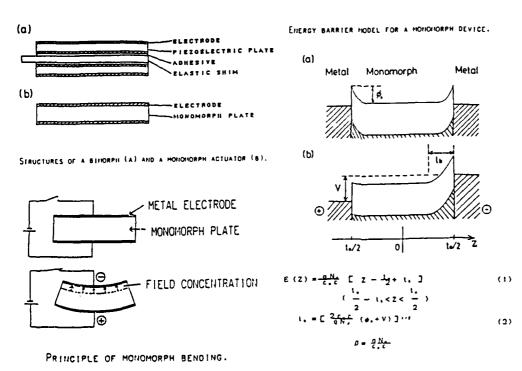
Piezoelectric Actuator

- · Compact Punch Head
- High Speed Punch System
- . High Precision Punch System
- · Silent Punch System
- Low Energy Using Punch System

MONOMORPH ACTUATORS USING SEMICONDUCTIVE FERROELECTRICS

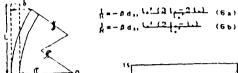
Kenji Uchino and Mikihiko Yoshizakı Department of Physics, Sophia University Kioi-cho 7-1, Chiyoda-ku, Tokyo 102

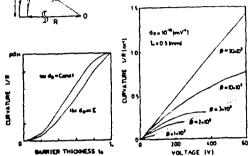
Hiroshi Yamamura, Kiyoshi Kasai, Naomichi Sakai and Hiroshi Asakura Advanced Materials Research Laboratory Toyo Soda Manufacturing Co.:Ltd. Hayakawa 2743-1, Ayase-shi 252

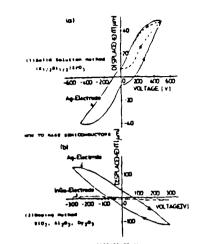


$$\frac{1}{R} = \frac{1.0}{1.2} \int 1001 \, t_0 \, d_{11} \, (Z) \, E_1 \, (Z) \, Z \, dZ \tag{4}$$

(5.a) consisting points (d), (Z) = d), (consists) (5.a) the Gradientity points (d), (Z) = d), (
$$Z - \frac{1}{2} + 1$$
, (5.b) (note $\frac{1}{2} - 1$, < $Z < \frac{1}{2}$)





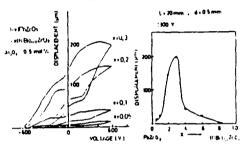


2

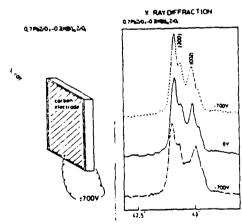
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LA) LEAD ZIRCOMATE BASED AND

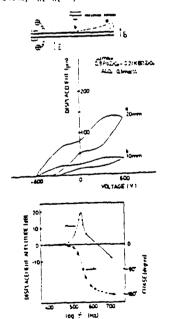
LA) DARILM TITAMATE BASED CERAMICS.



CHEUSTITOS GENERALICE OF HOLOTUTTH CHARGICAISTICS HI HE FE/203-18-1/28-1/27/2003 CEF-4HCS



87810	Lattice		Lattice	
(٧7	2#(*)	* (A)	2#(*)	e (A)
•	43. 46	4. 144	43 98	4. 116
+700	43. 66	4 144	43 98	4. 11R
-700	43-81	4 148	44.01	4 112



CLICATION COMMICAL RESONANCE IN A PRINCIPALAGED PRODUCTION LOTUSTOR.

Development of Electrostrictive Ceramics

S. Jomma, K. Maruta and J. Watanabe Hitachi Metals Ltd.

Object:

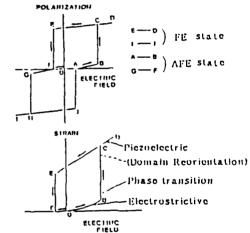
to obtain PTT ceramics with large strain for piezoelectric actuator.

Mechanism for the piezoelectric strains :

- (1) usual piezuelectric strain
- (2) domain reorientation
- (3) volume change of upit cell accompanied with phase transition (ex. AFE=FE)
- (4) electrostrictive strain

Antiferroelectric (AFE) - Ferroelectric (FE)

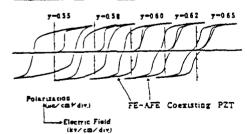
Phases Coexisting PZT Ceramic :



Composition:

(1-x)Pb(Zr,Ti,_,)O,-XSr(Ni;Znj_;Nbj)O, X=0.15 Z=0.25

Ferroelectric Hysteresis Loop (D-E Loop):



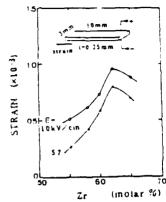


Fig.1 Composition dependence of strain after poling

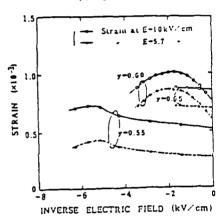


Fig. 2 Inverse electric field dependence of strain at E=10kV/cm and 5.7kV/cm

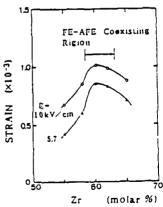
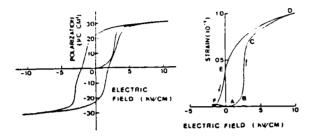


Fig.3 Composition dependence of strain after inverse electric field are applied.

Summary:

- 1. It was found that a large strain can be obtained using electrically induced phase transition in the FE-AFE phases coexisting ceramics.
- 2. The typical value of the transverse strain of this material is 1×10⁻³ at 10kV/cm.



3

TEMPERATURE DEPENDENCE OF ELECTROSTRICTION UNDER HIGH ELECTRIC FIELD

K ABE, O FURUKAWA, M KATSURA and K INAGAKI*

Tashiba Corp. *Marcon Electronics Co. Ltd.

TEMPERATURE COEFFICIENT OF ELECTROSTRICTION

 $\left(\begin{array}{c} \frac{1}{S} \frac{dS}{dT} \end{array}\right)$

$$\begin{cases} E = \alpha P + \beta P^3 + \gamma P^5 & E: electric field \\ P: polarization \\ S = QP^2 & S: electrostriction \end{cases}$$

$$\frac{1}{5}\frac{dS}{dT} = \frac{1}{9}\frac{\partial 9}{\partial T} = \frac{2}{\alpha + 3\beta P^2 + 5\gamma P^4} \left(\frac{\partial \alpha}{\partial T} + P^2 \frac{\partial \beta}{\partial T} + F^4 \frac{\partial \gamma}{\partial T} \right)$$

$$\left|\frac{1}{U}\frac{\partial Q}{\partial T}\right| \ll \left|\frac{2}{\alpha + 3EP^2 + 5\gamma P^4} \left(\frac{\partial \alpha}{\partial T} + P^2 \frac{\partial B}{\partial T} + P^4 \frac{\partial \gamma}{\partial T}\right)\right|$$

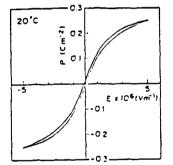


Figure 1 Electric field vs polarization for modified Pb(Zn_{1/3}Nb_{2/3})O₃.

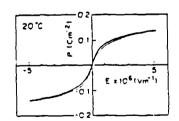


Figure 2 Electric field vs polarization for modified BaTiOs.

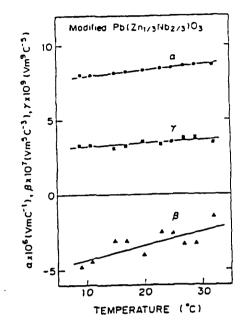


Figure 3 Temperature dependence of a, β and γ in $E = aP + \beta P^3 + \gamma P^5$.

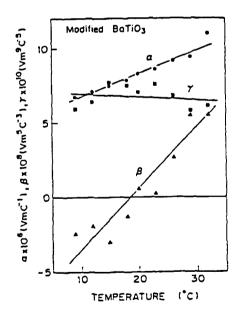


Figure 4 Temperature dependence of α , β and τ in $E = \alpha P + \beta P^3 + \tau P^3$.

Table 1. Values of α , β and γ in $E*\alpha P+\beta F^3+\gamma F^5$ at 20°C and their temperature coefficients

Ž X

Sample	Modified PotZn _{1/3} tlb _{2/3} 10 ₃	Modified BaTiO3	
a x10 ⁶ (VmC ⁻¹)	8.38	8 31	
8 x107 (Vm5C-3)	-3.39	5.81	
7 x10 ⁹ (Vm ⁹ C ⁻⁵)	3 46	67.4	
aa/aT x10 ⁶ (VmC ⁻¹ K ⁻¹)	0 042	0 1 5 7	
$a\beta/aT = x 10^7 (Vm^5C^{-3}K^{-1})$	0 095	4 154	
a7/aT x10 ⁹ (Vm ⁹ C ⁻⁵ K ⁻¹)	0.0024	-0.18	

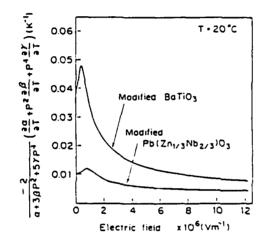


Figure \int Calculated curves of $\frac{-2}{\alpha + 3\beta P^2 + 5\gamma P^4} \left(\frac{a\alpha}{aT} + P^2 \frac{a\beta}{aT} + P^4 \frac{a\gamma}{aT}\right)$ as a function of electric field.

CONCLUSION

For a multilayer electrostrictor using modified lead zinc niobate

- Temperature coefficient of electrostriction < 12% / °C at 20°C.
- 2 Utilization under high electric field favorable for temperature stability

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PREPARATION AND CHARACTERISTICS OF NEW MONOMORPH ACTUATOR

N.SAKAI, K.KASAI, YAMAMURA and K.UCHINO Advanced Material Research Laboratory, Toyo Soda Manufactuaring Co., LTD and Sophia University

ABSTRACT

Bending phenomenon was newly obserbed in a single ceramic plate of $8aT_1\theta_3$ which was dozed by small amount of $Si\theta_2$ and $Al_2\theta_3$ or $3b_2\theta_3$. The bending mode may occur by the presence of potential barrier between silver electrode and ceramic semiconductor, as a result of inhomogeneous distribution of an electric field and also by inhomogeneous polarization in oxidized surface layer.

Introduction

There are two modes of ceramic actuator, that is, longitudinal and bending modes. The bending mode can be realized in the bimorph-or unimorph-type elements. Fig.1 shows a schematic diagram of the unimorph -type element. On the other hand, in the present study, it was found that the ceramic single plate of BaTiO₃ which was doded by small amount of SiO₂ and Al₂O₃ or Nb₂O₃ showed the bending effect by applying external field. (Fig.2)

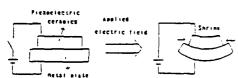


Fig.1. A schematic diagram of the unimorphtype element.

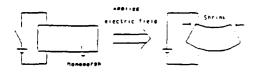


Fig. 2. A schematic diagram of the monomorphtype element

EXPERIMENTAL

after 8aTiO₁ was palineitled with 5 mol% 5:0₂ and 2-5 mol% Al₂O₁, the powder was rubber-pressed to compacts. Sintering was performed at 1250°C for various periods, 1 to 15 hrs. in air. 8aTiO₁ dooed by Nb₂O₃ (0.1 to 1 al%) was also prepared in the similar procedure apove-mentioned. Sintering was performed at 1300°C for 1 hr. Hetal electrodes such as Ag. Au. Ga-in were used to check the electrode effect. Bending effect was measured by non-contact sensor method. The sample size measured was 40 mm length. 15 mm width, and 0.5 mm thickness. The measurement was procedured at the position of 28 mm far from the fixed end.

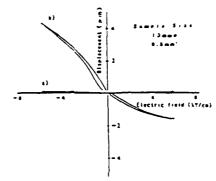


Fig. 2. Displacement versus applied electric field for the sample with Ag electrode. Displacement was measured by contact method using potentioneter.

- a) hon-doped Balion
- b) 5 mal% SiOz and 2 mal% AlgO, doned Batio,

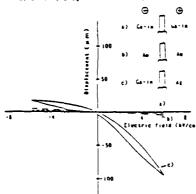


Fig. 4. Electrode dependence of displacement-applied electric field characteristics for the SiO₂: Al₂O₃ doped 8aTiO₃.

- až Garin, Garin.
- b) Au , Au,
- c) Garin. Ag (Ag paste vas fired at 750°C).

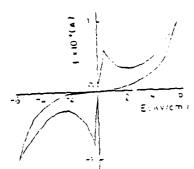


Fig.5, Current-electric field characteristics for the SiO₂-al₂O₃ domed baTiO₃, with ag electrode.

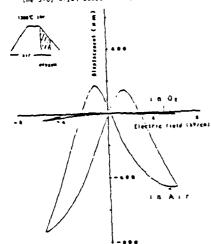


Fig. 6. Displacement versus applied electric field for the sample fired at 1200°C for 1 hr in different atmosphere and cut to the plate of U.S. we thickness from the surface.

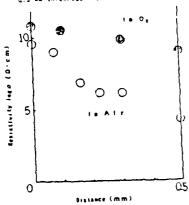


Fig 7. Resistivity as a function of distance from surface to inside. The resistivity was deadured after the unidized surface was stices. This procedure was repeatedly some many sides.

a) fired in air and then in seygen tas on fines stage.

B) fires in air.

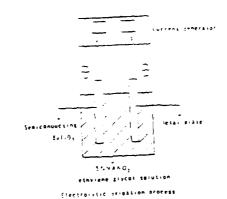


Fig. 8. Diagram of electrolytic oxidation

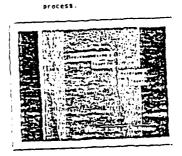


Fig. 2. SEM micrograph of electrolytically maidized layer, which was daidized at the current density of 2 ma/coffor thr. The 0.1 miles however 8 miles sintered at 1200°C for 1 hr was used.

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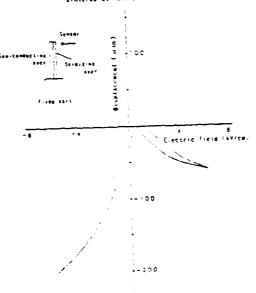
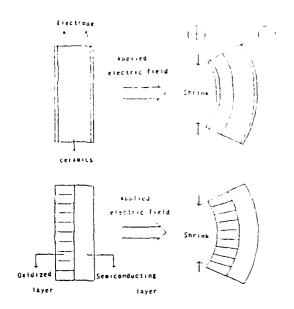


Fig. D. Dissiscement versus copied miectric field for the surface-painting diste which was non-tontally but in half and then fired as 000 T for in him air.



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Fig.11. Diagrams of two different types of bending mechanism.

Summary

- We got a new type's actuator of bending mode, which could occur bending phnomenon in a single plate of ceramics. We named it "MONOMORPH".
- 2. We can guess that it may occur by two major mechanisms as follows:
 - a) Presence of potential barrier between silver electrode and ceramic semiconductor.
 - b) Presence of resistivity distribution as a result of innomogeneous oxidation.

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APPLICATIONS OF POLYMERS TO VLSI PACKAGING

- . INEXPENSIVE
- . EASILY FORMED
- SOLDERABLE
- HIGH DIELECTRIC STRENGTH
- . LOW DIELECTRIC CONSTANT

Lionel M. Levinson

Ganetal Electric Company
Schonaetady NY

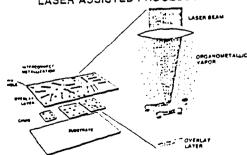
LASER PROCESSING OF POLYMERS FOR PACKAGING

- METALLIZATION BY LASER DEPOSITION
 - . NON-CONTACT
 - MASKLESS
 - LOW TEMPERATURE
 - . SELECTIVE
 - GOOD STEP COVERAGE
- . POLYMER MACHINING BY LASER PHOTOETCHING
 - SELECTIVE
 - . MASKLESS
 - LOW TEMPERATURE
 - NON-CONTACT
 - HIGH RESOLUTION

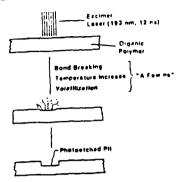
REQUIREMENTS OF POLYMERS FOR ELECTRONIC PACKAGES

- . PROCESSABILITY
- . ADHESION
- . HIGH DIELECRIC STRENGTH
- . MOISTURE/SOLVENT RESISTANCE
- . THERMAL STABILITY
- · PATTERNABLE
- REWORKABLE

LASER ASSISTED PROCESSING



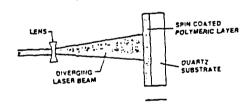
EXCIMER LASER PHOTOETCHING OF POLYMERS



FACTORS AFFECTING PHOTOETCH RATE

- LASER FLUENCE
- ABSORPTION COEFFICIENT
- . POLYMER STRUCTURE
- . LASER WAVELENGTH

EXPERIMENTAL DETERMINATION OF PHOTOETCHING RATE



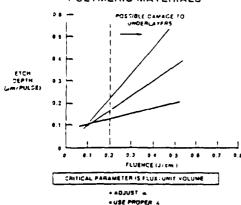


THRESHOLD DAMAGE LEVELS FOR VARIOUS FILM-SUBSTRATE COMBINATIONS

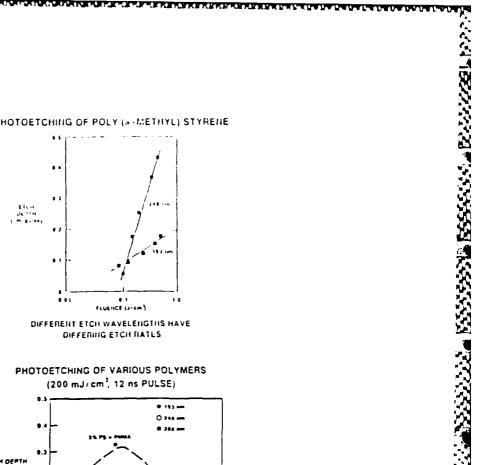
SAMPLE	λ	(mJ/cm ²)
		200
ALON POLYIMIDE	193 nm	
SI, SIO z	193 nm	>400
•	193 nm	>400
Al on Si	308 nm	140
AI ON MYLAR*		246
Cr ON QUARTZ*	308 nm	240

* ANDREW, ET AL. APPL. PHYS. LETT. 43, 1076 (1983)

EXCIMER LASER PHOTOETCHING OF POLYMERIC MATERIALS

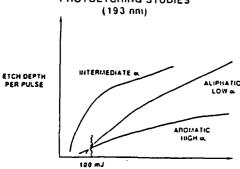


PHOTOETCHING OF POLY (x-METHYL) STYRENE



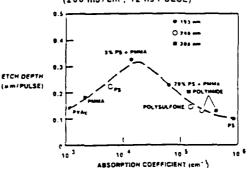
DIFFERENT ETCH WAVELENGTHS HAVE DIFFERING ETCH RATES

PHOTOETCHING STUDIES



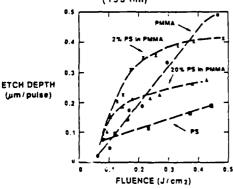
FLUEHCE (mJ/cm²) INTERMEDIATE ABSORPTION COEFFICIENT CAN GIVE THE HIGHEST ETCH RATE

PHOTOETCHING OF VARIOUS POLYMERS (200 mJ/cm2 12 ns PULSE)



THERE EXISTS A GENERAL POLYMER ETCH RATE VERSUS ABSORPTION COEFFICIENT CURVE FOR MANY POLYMERS

PHOTOETCHING OF POLYMER BLENDS (193 nm)



SMALL AMOUNTS OF POLYSTYRENE (PS) IN POLYMETHYLMETHACRYLATE (PMMA) DRAMATICALLY ENHANCES THE ETCH RATE OF PMMA

CHARACTERISTICS OF LASER PHOTOETCHING

- . A FLUENCE THRESHOLD EXISTS FOR PHOTOABLATION
- AT LOW ABSORPTION COEFFICIENTS, LITTLE ETCHING OCCURS SINCE ABSORBED ENERGY PER UNIT VOLUME IS TOO SMALL
- AT YERY HIGH ABSORPTION COEFFICIENTS, PHOTONS DO NOT PENETRATE THE POLYMER AND LITTLE PHOTOETCHING OCCURS
- THE MAXIMUM POLYMER ETCH RATE OCCURS AT INTERMEDIATE ABSORPTION COEFFICIENTS
- FOR PRACTICAL APPLICATIONS, THE POLYMER ETCH FLUENCE MUST BE LIMITED TO AVOID DAMAGING UNDERLYING COMPONENT METALLIZATION

CONCLUSIONS

- . EXCIMER LASER RADIATION CAN BE USED TO PHOTOETCH WITHOUT DAMAGE TO VLSI CIRCUITS
- . POLYMER ETCH RATE CAN BE OPTIMIZED BY
 - ADJUSTING POLYMER ABSORPTION COEFFICIENT
 - ADJUSTING IRRADIATION WAVELENGTH

CHARACTERIZATION OF THE ROLE OF EXCESS MGD AND

PBD IN LEAD MAGNESIUM NIDBATE

37

HUI-CHIEH WANG

ADVISOR: DR. WALTER A. SCHULZE

NEW YORK STATE COLLEGE OF CERANICS

AT ALFRED UNIVERSITY

ALFRED UNIVERSITY

ABSTRACT

Near phase pure perovskite Lead Magnesium Niobate (PMN) was produced by reacting P2O with MgHb2Og at 800°C. Powder x-ray diffraction atudies support the conclusion of an earlier study that excess MgO produces the highest percentage perovskite phase PMN. Dense ceramic was prepared for characterization by sintering at 1200°C. Scanning electron spectroscopy combined with energy dispersive spectroscopy were conducted on both fractured and polished cross sections in an attempt to confirm the observations of Coo. Depth profiling on intergranular fracture cross sections was used to dertermine the average level of excess PbO and MgO in the grain boundary region as characterized by secondary ion case spectroscopy. Microstructural and dielectric constant information is discussed as to the effect of excess PbO and MgO on PMN ceramic.

CHENICAL COMPOSITIONS:

FAURICATION:

		MgNb20e FDHMATION	Phigs/ands/a0s FORMATION
PHN-SID (PDNg	1/21102/202)		
		Manifor Da. EXCESS MgQ	HOID, G. IPOG. EXCESS Pb
PHH-2 Mol I MgO		-BALL MILL	BALL MILL
AUII-5 MOT 7 WAA		-CALCHE 1000°C	CALCINE 800°C, 4 Hrs
	PHII-2 Hol I Pb0	8 irs	enx
PHN-5 Hol I MgD		100	PYA. PRESS
	PHH-5 Hol I PbO	-20	STITEN 1200°C, 1 IF
PHH-10 Hol \$ Mg0			XMO SINIEMED PELLETS
Buik properties of	lead magnesium minhote	XIIO F	PHASES IDENTIFICATION

Committee	Street Streetly	Fired density		1 rt.	8170 8170	AFIER DO ME-CALCINATION 88-100			
PH-510	4 7418 05	7 5216 42	# 10 15	1010 06	\$.1 _{[1} \$	I PENOVSKITE PO	IST CALCINE	בואוסים רפונבוג	
PMI-25 H10 \$161 55 H50 PMI-185 H90	4 7510 13 4 5310 05 4 7410 65	7 8310 02 7 8750 02 7 8360 02	0 10 0 0 10 0 1010 15	2010 09 3419 94 54 0198	2 110 0 2 211 2 2 711 4	P94-510	9G 3	97 4	
Print PSQ Print PSQ Print PSQ	4 8110 62 4 8110 62	3 8318 B4	0 10 0 2 7510 01	1 8110 55 4010 02	1 9:0 7 1 9:0 8	1781 28 1170 1781 58 1470 1781-108 1470	97 3 97 6 97.9	100 93 7 100	
	ity greens						84 5 87 8	970 - 0 97 - 9	

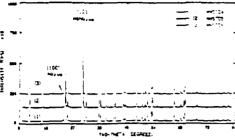


Figure 31. IRO for the second calcines of stoleniemetric moralise



Figure 8. BSE image of the polished and etched surface for an over-fired PMM-55MgO sample. (Magnification=1000X.)

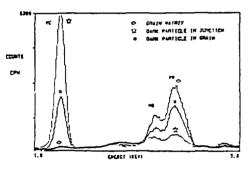


Figure 1. ESS sectors on the collimed and status surface for an occurrance monthings.

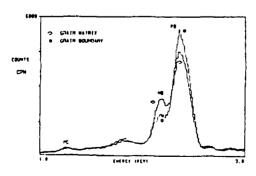


figure 11. (88 spectrs on the freetern confers for PME-21FbB.



Figure 10. BSE image of the fracture surface for PMN-23PbO. (Magnification-6000X.)

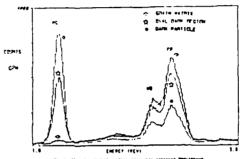
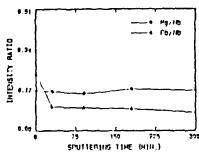


Figure 16. 8 prisoned serfers of combin conformal pro-topologic ser profitored with tropps of so emission current of 15 set, this prives the EFT continue the



Figures 17. A polithed surface of doubly sintered PMM-101MgD was apottered with argon at an emission current of 10 MA for 250 minutes. These show the lenges of the sputtered surface at the ragnifications of (a) 2000X, SE mode and (b) 8000X, BSE mode.

(a)



Control of the state of the sta

Figure 21. The SIMS depth prolife on the PMM-SIFbO as-fired surface sputtered with argon for 300 minutes at an emission current of 10 ml.

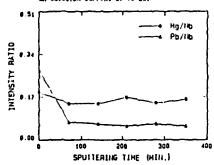


figure 20. The SIMS depth prolife on the PMM-STO earfired surface sputtered with argon for 7 hours at an estasion current of 10 mL.

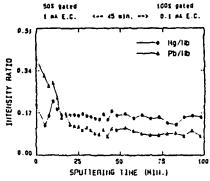


Figure 13. The SIMS depth profiles of (a) PHH-STD.

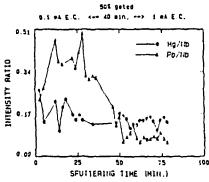
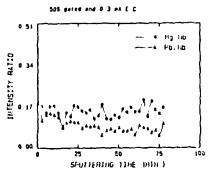


Figure 13. The SIMS depth profile of (b) PMM-25MgO.



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Figure 13. The SIMS depth profile of (a) PMN-21PbO.

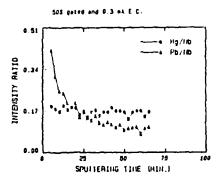


Figure 13. The SIMS depth profile of (f) PMH-55PbO.

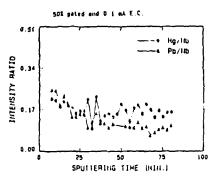


Figure 13. The SIMS depth profile of (c) PMH-55MgQ.

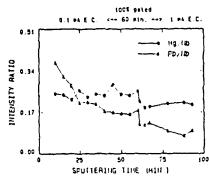


Figure 13. The SIMS depth profile of (d) PMH-105MgO.

DIELECTRIC PROPERTIES OF PWN

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Per 71 =0	18-00	-16	12863	-13	14790	-1	13700	-1	17700		
	10-400	- 16	18406	-12	17700	٠,	19800	-1	1400	7	
1 Stands	>4800	-14	23400	- 75	\$1800	-7	50500	-1	10000	7	
n:	:0100	-:4	9870	-10	9407	-4	8000		830 0		
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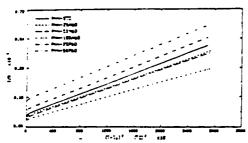
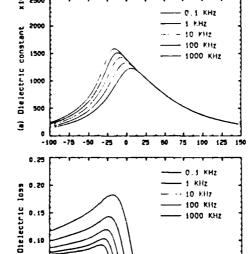
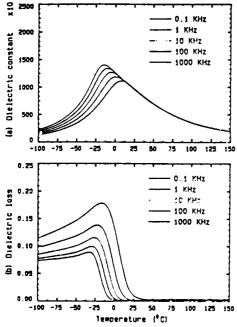


Figure 28. Plot of 1/K vs. $(\overline{t}-\overline{t}_0)^2$ for all consentaions of Piol

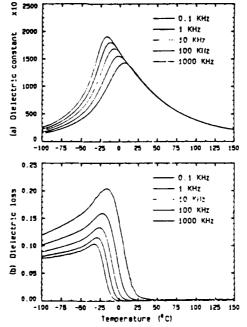


-100 -75 -60 -25 0 26 50 78 100 125 150 Temperature (°C) Figure 23. Temperature expendence of (a) districtric constant and (b) districtio loss for PMI-ZDAyO

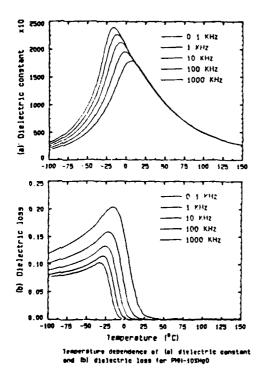
ā 0.05

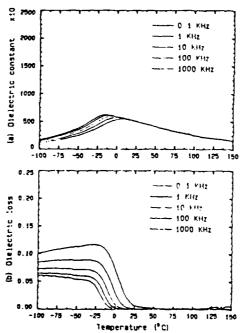


Temperature dependence of isl dielectric constant and (b) dielectric loss for PMSI-SID



Temperature dependence of (a) dislectric constant and (b) dislectric loss for PME-53040





Temperature dependence of (a) disjectric constant and (b) disjectric loss for PNN-SEPDO

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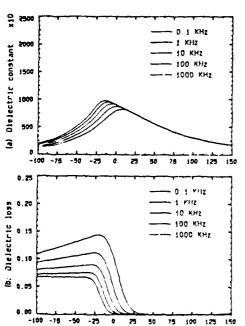
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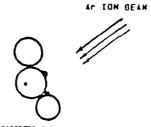
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HODELLING



-78 -50 -23 0 25 50 75 100 125 150
Temperature (°C)
Temperature of (a) dislectnic constant and (b) dislactnic loss for Pet-22000



■ : DISCRETE EXCESS POD

PRESENT IN GRAIN BOUNDARY

: DISCRETE EXCESS MOD PRESENT

IN THE GRAIN OR IN GRAIN BOUNDARY

: HIGH POD CONTENT LAYER PRESENT

FOR ALL GRAINS

Figure 29. A modeling for the microstructure of lead magnesium nicetate.

SUMMARY

- -TOWPOSITIONS CONTAINING EXCESS MGO, MGO IS PRESENT
 ETHER AS SUBMICTON SPHERICAL DIGUSCONS IN REPOVENING
 SPAINS, OR AS COCCRETE COCLARED SPAINS.
- —SIMS IDSERVES PRO-RICH LEYER ON THE SURFACE OF THE SHAIRS FOR $\mu_{\rm sub}$ COMPOSITIONS
- THE STATES AND ENHANCES CIELECTRIC CONSTANT BY INCREASING THE CHARLING CLAMPTER AND/OR CHANGING THE CHARLINGIC CONSTANT OF THE CHARLING

TRIVALENT IMPURITIES IN BATIOS

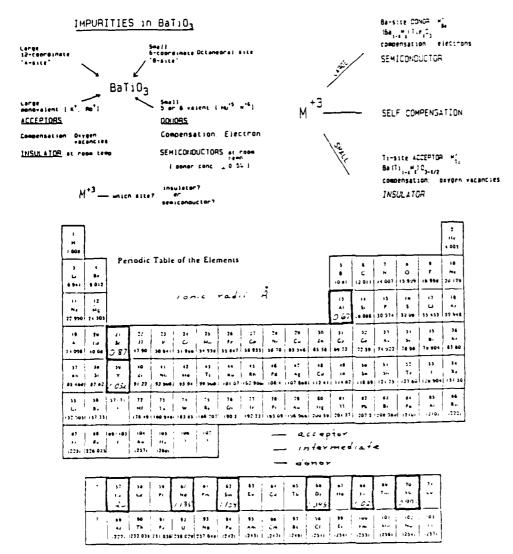
K. TAKADA*, R. Y. LEE, S. R. WITEK, and D. M. SMYTH

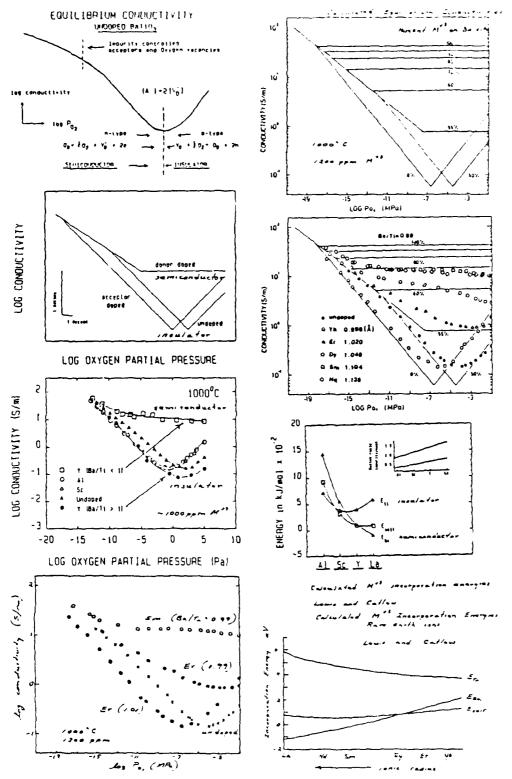
Materials Research Center, No. 32

Lehigh University Bethlenem, PA 18015 U.S.A. * Sumitomo Metal Mining Co., Ltd.

Central Research Laboratory 3-18-5, Nakakokubun Icnikawa, Chiba, JAPAN

ABSTRACT: The effect of small additions of trivalent metallic impurities on the electrical conductivity of Ballo, has been studied for samples having an excess of either BaO or IIC₂. The properties change gradually with the ionic radius of the impunities, indicating that those of intermediate size occupy both Ba and Ti sites in varying amounts that depend on the Ba/Ti ratio.



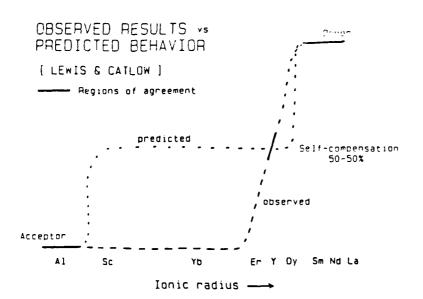


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SUITIARY

as a consistency of the second of the contract of the contract

i. LARGE M*3: Lo*3, NJ*3, Sm*3

Occupy Ba-sites

Danors - semiconductors

2. SMALL M*3: Al*3, Sc*3, Yb*3

Caupy Ti-sites

Acceptors - Insulators

3. INTERMEDIATE SIZE : Y+3, Er+3

Con occupy either site Division depends on:

size Ba/Ti ratio

Can be insulator or semiconductor

4. Less self-compensation than predicted by theoretical calculations

ACKNOWLEDGEMENT: This research was supported by the Office of Naval Research, the National Science Foundation, and Sumitomo Metal Mining Co., Ltd.

W19

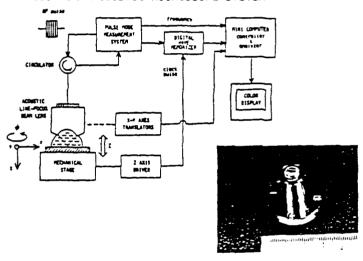
LINE-FOCUS-BEAM ACCUSTIC MICROSCOPE SYSTEM FOR NONDESTRUCTIVE EVALUATION OF ACCUSTIC INHOMOGENEITY ON PZY WAFERS FOR SAW DEVICES

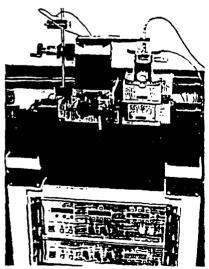
N. CHUBACHI and J. KUSHIBIKI

Department of Electrical Engineering, Eaculty of Engineering, Tohoku University, Sendai 980, Japan

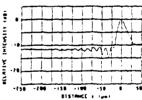
The line-focus-beam acoustic microscope system has been developed which can inspect elastic properties of externals over an area of 55mm I 55mm with a measurement accuracy better than 10.03% in velocity measurements. The evaluation of acoustic inhomogeneity on PZT ceramic wafers for 55W devices has been made successfully with this system. Large variations in SAW velocity have been detected on a wafer sample and also among wafers.

LINE-FOCUS-BEAM ACOUSTIC MICROSCOPE SYSTEM





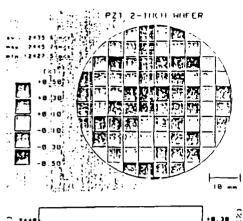
VARIATION OF ACOUSTIC PROPERTY

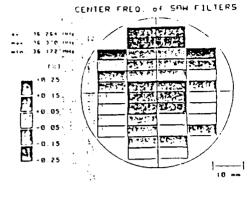


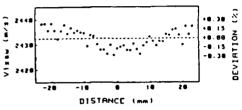
Typical Viz) curve on water/PII-ceronic measured with acoustic line-focus been at ZZSME

Table 1 Average velocities of leaty SAVs at the conter of nine P21 ceromic meters

,	1+41
1	74.11
1	7031
	2+31
	1429
•	1424
	1 - 11
	2421
	7 . 21







3535 P335

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VISOU OF PZT WAFER

18 --

COMPARISON WITH SAW FILTER CHARACTERISTICS

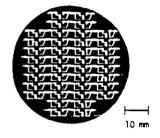
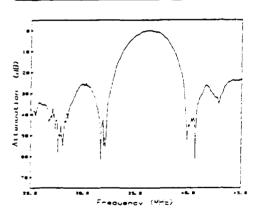


Table 2 Parameters of normal IDTs of SAW filters.

Liectross -1623 (189)	Cae √Lccn ∶µæ/	Number Slactrone	ADPTEURE 4Eh	Propedation Distance
16.48	16 49	\$ 5	 1	3 69



Frequency response of SAW filter.

W20

ELECTRICAL PROPERTIES OF (Sr.Ca)TiO, BASED CERAMIC VARISTORS

N.YAMAOKA. M.MASUYAMA. AND J.FUNAYAMA Central Research Institute. TAIYO YUDEN CO..Ltd. 1660 Kamisatomi. Haruna-machi. Gunma-ken. Japan.

ABSTRACT

Electrical properties of (Sr.Ca)TiO: based ceramic varistors were investigated. Surge absorption characteristics of samples of which the basic semiconductive ceramics were fired in two reducing atmosphere were examined in relation of to the resistivities of the semiconductive ceramics, the impedance of the ceramic varistors and so on. The resistivity was $0.14\,\Omega\,\text{cm}$ at sample(A) or $0.09\,\Omega\,\text{cm}$ at sample(B), respectively. The resistivity was decreasing with increasing of H2 concentration in the firing process. The surface resistance of the semiconductive grain after a diffusion process was $5.5K\Omega$ at sample(A) or 2.1 Ω cm at sample(A), respectively. Sample(B) indicated anexcellent surge absorption characteristics in the region of high impulse surge voltages compared with that of sample(A). The depressed voltage was 280V at sample(B) or 340V at sample(A). respectively, when a high impulse surge of $5000V(3/20 \mu s)$ was supplied to samples. The difference of this depressed voltage is originated from the resistance of the semiconductive grains.

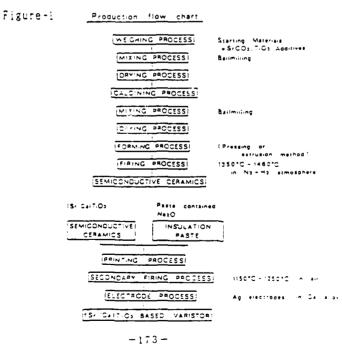
INTRODUCTION

Microstructures and some electrical properties of SrTiO₃ or (Sr,Ca)TiO₃ based ceramic varistors were reported by our previous papers. It is well known that (Sr,Ca)TiO₃ based ceramic varistors have a high apparent permittivity and a high surge capability. The these varistor characteristics are well unknown in the region of a high current or a high voltage surge.

In this work, we present the varistor characteristics in a high impulse surge region in the relation to the resistivity of the based semiconductive ceramics, the impedance of the varistors and so on.

EXPERIMENTAL

The starting materials used in this study were high purity materials of SrCOs. TiOs CaCOs. No.20s and small amount of additives. The basic components were weighed respectively and the powder mixtures were ballmilled. The mixed powders, with an aproupriate organic binder, were pressed into tablets under a pressure of 10°Pa. After burning the binder, the tablets were fired at a temperature of 1380°C -1420°C in 98% Nz -2% Hz or 90% Nz -10% Heatmosphere, respectively. In order to make Bi structure, a paste including Na₂O was printed on the surface of the based semiconductive ceramics. The printed specimen were heat treated at 1150°C-1250°C in air for the grain boundary diffusion of the printed materials. In-Ga alloy were attached to the surfaces of the semiconduct ive ceramics, for the measurement of the resistivities. The surface resistance of the based semiconductive grains were measured using a micro manipulator after the metaloxide diffusion. Silver electrodes were fired on the surfaces of the ceramics. The capacitances were measured by a capacitance bridge. The impedance at various frequency was measured using an impedance analyser(YHP:model = 4191). The current was measured by an amphere meter. A standard impulse wave of $8/20\,\mu$ s in width was used to examine the surse capabilities of (Sr.Ca)TiO: based ceramic varistors. Production flow chart is shown in fig. -1.



TERRETS ARD PILLUSSIUMS

Table-i

Electrical Properties of Sr. callio, Variators, (AloriB).

Seamle Ho.		Carcencel 1201	@ 11m4-410m4	Vl=A
Ä	0.11(Ω -e=	[[9700(#F11]20(#42)]	17.2	3.0(1)
ß	0.09(Ω -c=	[20100(př)] 60(=Q)]	17.5	[81.5(V)

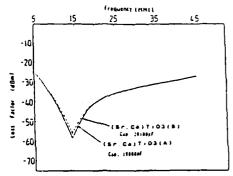


Figure ? Freileich dependence of (Sr.Ca)TiO, Ceranic Varisturs

The impedance at the resonant frequency of samples were $120n\Omega$ at sample(A) and $85n\Omega$ at sample(B), respectively as shown in fig -2. These results seem to indicate that the resistivity of the based semiconductive grains of sample(B) is evidently lower than that of sample(A).

Figure-3 I-V curve of the based semiconductive grains

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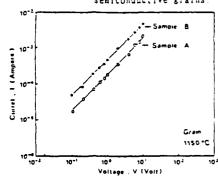


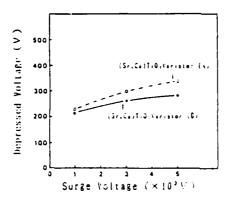
Figure-3 shows a I-V characteristics of the based semiconductive grains of sample(A) and (3) Au pattern was southered on the polished surface of a (\$r.Ca)TiO, based variators for the assuration of the I-V curve using a micro manipulator method so shown in figure-4. The surface resistance of the grain measured at I/vd were 1 iKO at sample(B) or 5 5KO at sample(A) respectively If let us suppose the measured surface area(CDx IOu m²) as a volume(20xisiOu m²) aproximately the resistivity of the grain is Galculated. These are 0.42 Ω cm at sample(B), or 1 IO cm at sample(A), respectively.

K

Finuse-5 shows a 1-V characteristics of sample (A) and sample(U). The 1-V curve of both samples is alrest the same line in a current resion below 1000mA. However the 1-V curve of sample(B) showed a more unrised line as can be seen in fig. 5. This varietor can flow a current of 230A/cm timouth the ceremits when the bissing of 2000-V/cm was supplied to a varietor. While, a calculated flowing current through a grain was ab 250A/cm as a supposition of a column grain roughly. This value seems to be corresponding to that in 1-V curve of sample(B)

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Figure-6 Supplied Surge Voltage vs. the depressed Voltage



Surge shorted to these campies were examined when various high imposes volumes (8/20 ms) were supplied to the samples. The results are shown in figure-8, then the samples voltage of 5000 v. as applied to samples (pm dot pressed voltage was 340 v. at sample(1) or 730 v. at sample(2), respectively. The surge absorber in capability of sample(2) was higher than that of sample(A) in a high surge region above 1000.

As a consequent, this difference of surge absorber capabilities between sample(3) and sample(3) is originated from the resistance of the sample(4) and sample(5) and sample(6) is originated from the resistance of the sample of the campic order of the sample of the capabilities of

CONCLUSION

The impulse surge absorption capabilities of (Sr.Ca)TiO, based varistors were examined in the relation of other electrical characteristics. As The two samples were fabricated by the difference of the reducing atmosphere in the firing process of semiconductive ceramics.

As the results.

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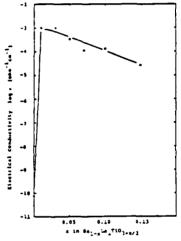
- 1. The resistivity of the basic semiconductive ceramics was 0.14 Ω cm at sample(A) or 0.09 Ω cm at sample(B).respectively.
- 2. The impedance at the resonant frequency of the ceramic varistors were $120\,\mathrm{m}\,\Omega$ at sample (A) and $65\,\mathrm{m}\,\Omega$ at sample(B), respectively.
- 3. I-V curve of sample(B) showed a more abrupt uprised line in a high current region compared with another one. Whereas, it was almost the same in the lower region below 1000V.
- 4. The surface resistance of the semiconductive grain was $2.1 \mathrm{K}\Omega$ at sample(B) or $5.5 \mathrm{K}\Omega$ at sample(A), respectively. It is supposed that a flowing current through the grain of sample(B) is ab.250A/cm² at 2000V roughly. This value seems to be corresponding to that in the I-V curve of the varistor.
- 5. When the impulse voltage of 5000V was supplied to samples, the depressed voltage was 340V at sample(A) or 280V at sample(B). respectively.

As a conclusion, it is considered that the defference of surge absorption capabilities between sample(A) and (B) is originated from the resistance of the based semiconductive ceramic grains.

Defect Structure and Electrical Properties of La-Doped Barium Titanate

S. Shirasaki, H. Haneda and M. Sugimoto

National Institute For Research in Inorganic Materials, Tukuba Science City *T.D.K. Co., Ichikawa, Chiba



riq. Electrical conductivity as a function of x in Communition Sa_{1-x} in TiO_{1-x/2} sactored at 1280°c and quantities down to room tengerature.

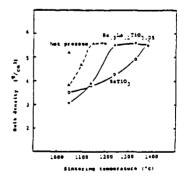


Fig. Buik donaxty as a function of sintering temperature for quantum and het presend-quantum be just 1700,05 and quantum titeness.

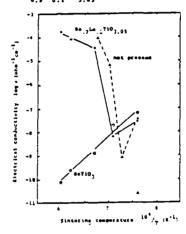


Fig.; Electrical conductivity as a function of wintering temperature (L/T) for quescend and not pressed-quenched Sa_isa_[10]_03 and quenched pure betien titenate.

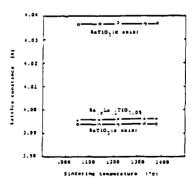


Fig. w Settle comptance as a function of sinterine temperature for dumnened Ba₁₉ Ma₁₂T10_{5.05} and pure barium citanete.

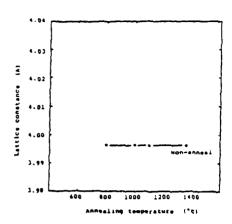
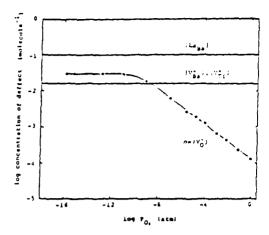


Fig. Lattice constance as a function of annealing temperature for Sa pla 1^{TiO}3.05 sintered at 1380°C. Annealing period is one week respectively.



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Fig.12 Calculated.commentrations of point enfects as a function of Pop of Larannon material. The level of Yo was calculated from an measurements and assuming m-(Yel) and ph. - 8.3 cm²/Y-sec.

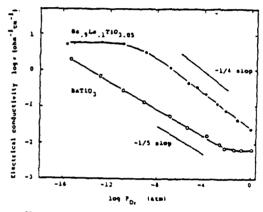


Fig. " Electrical conductivity as a function of P_{Q_g} for $Ba_{-g}La_{-1}^{-210}3_{-0.5}$ and pure barium titanate at 1200°c.

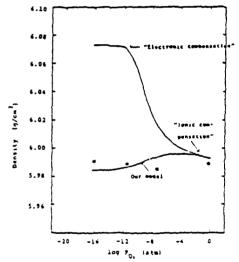
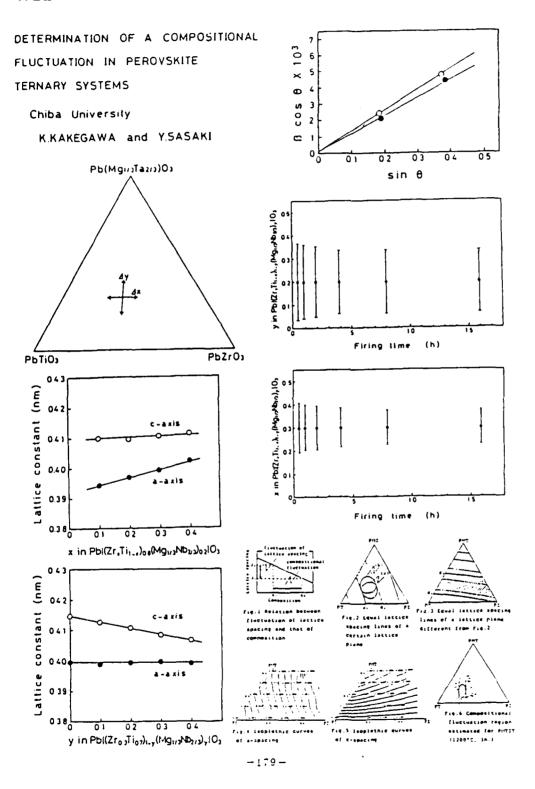
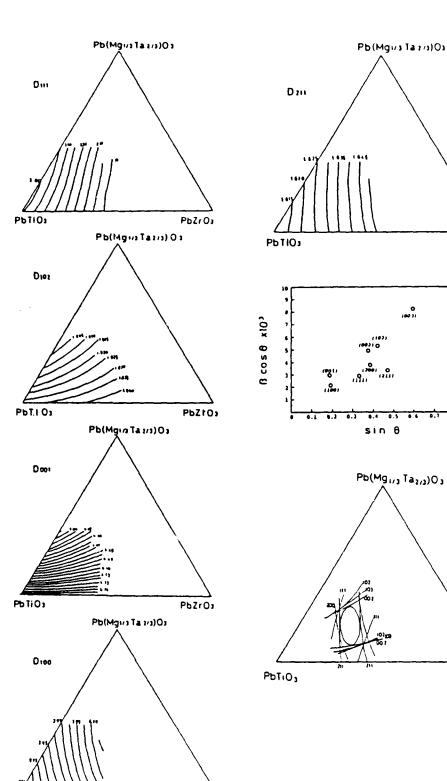


Fig. Calculated constition as a function of Pofor"Bagginag, TIC3.05" on a basis of two models. One is based on a preferential occurrence of "electronic communication" at lower Po- and ionic communication at history Po-, and anacors, our model. Classed points





PbZrOs

PbZrO₃

117.5

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PbZrOs

PhTIOs

PROPERTIES OF THE AIN CERAMICS

T. TAKAHASHI, K. ANZAI AND N.TAKADA

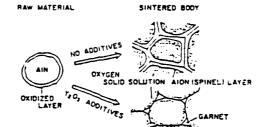
New Materials Department, Tosniba Corp. Toxyo, Japan

K.SHINOZAKI

Metals & Ceramics Laboratory, R & D Center, Toshiba Corp. Kawasaki, Japan

Trends of Ceramic Substrates and Packages

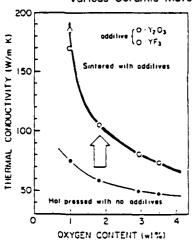
Trends of electronic equipmets	Requirements to Substrate & Packages	Examples
High power	High thermal conductivity	AIN , DBC Be O
Minieturizetian	High density	Multi layered
High speed	Lew dielectric constant	Glass/ceramics Camposite



HIGH THERMAL CONDUCTIVITY MECHANISM

Thermal conductivity (W/m·k) 1000 3000 300 C (Diamond) 10 20 BeO 30 SIC 50 100 == A1, 0, Doserved Calculated or 200 Single Crystal

Thermal Conductivity for Various Ceramic Materials



RELATION BETWEEN OXYGEN CONTENT OF ALM RAW POWDER AND THERMAL CONDUCTIVITY.

TOSHIBA

PROPERTIES OF CERAMICS FOR SEMICONDUCTOR SUBSTRATES

ltem.	Unit	AZN (Yoshbe)	A1,0,	8=0	Sic
Thermal conductivity	W/m. K (RT)	170	20	250	270
Volume resistivity	D.em (RT)	>10"	>IC **	>10**	>103
Diesectric strength	kV/cm(RT)	140-170	100	100	0.7
Dielectric constant	€ (RT, IMHz)	8.6	8.8	6.5	40
Detectric loss	IC" ion à (IMHz)	5-10	3	5	500
Thermal expension coefficient	IC **C (RT=400°C)	4.5	7.3	8	3.7
Density	Ç/Cm ³	3.3	3.9	2.9	3.2
Young's modulus	10"4kg/mm2	28	3.7	3.2	> 4 8
Figures strength	kg/mm ²	40-50	24-261	17-23 i	45

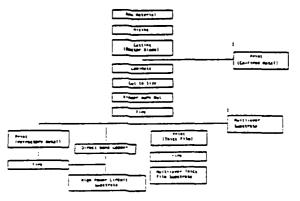
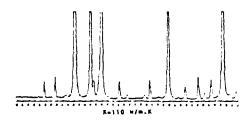
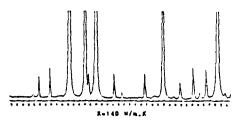
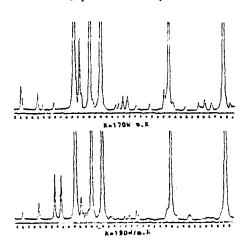


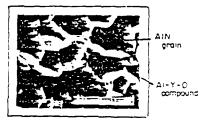
Fig. 2 Flow Chart for AIN Substrate





X-ray diffraction pattern





Microstructure of the AIN ceramics

(Reaction)

Oz (Process Contamination)

mixture	sintered body
AIN traw material) Al ₂ O ₃ (Impurity,-0.8 mol %) Y ₂ O ₃ (Additive, ~ 0.5)	$\Rightarrow \frac{\text{AIN+}}{\text{mAi}_2\text{O}_3 \cdot \text{nY}_2}$

Thermal conductivities and compounds in the AIN ceramics

F - value	Compounds
110 W/m·K	YAG > AION
140	YAG
170	YAL > YAG
190	YAM - YAL > 143
235	YZON - YAM

YAG 31203 5A1203 YAG 1203 Al203 YAM . 21203 A1203

 Moiar fraction, Y2O3/Al2O5 has the probability to be a good index to estimate thermal conductivity and to judge the whether the manufacturing process is appropriate or not

Suggested applications

- · Power transistor module
- · Laser diode heat spreader
- · Power hybrid IC substrate
- LSI, VLSI package
- · Electrical insulator with high thermal conductivity

AlN Substrates and Applications





(K~180)



CBC (Direct Bonded Copper)





(K~70) Bare substrates



Giant transistor



Mo metalized



Power amplifier



Au thick film



Chip carrier

W24

NEW GENERATION POT - POLYMER COMPOSITE MATERIAL FOR HYDROPHONE APPLICATIONS

IAN BEDWELL AND IDENER JANDERA

Plessey Australia Pty. Ltd., Electronic Systems Division, Meadowbank, NSW, 2014, Australia.

GEOFF GILLMAN

Weapons Systems Research Laboratory, Defence Science and Technology Organization, Defence Research Center, Salisbury

ABSTRACT: A PIT Polymer Composite Hydrophone Matrix has been developed. In comparison to other new generation materials, it has the highest acoustic performance. External tests have been performed by N.R.L., Orlando, U.S.A. and Plessey Naval Systems (P.N.S), U.K. to assess the materials for Navy Hydrophone Applications. The Data as presented here snow promising performance.

1. INTRODUCTION

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Traditional Lead Tirconate Titanate (PIT) Hydrophones and Sensors utilize geometry and specialized designs to obtain their acoustic performance. However, they have drawbacks of fairly high density, rigid and somewhat brittle in nature, even though they are very well understood and are produced in enormous quantities. Lately there have been several new generation materials available, which have made the concept of Isotropic large area Hydrophones, feasible at a realistic cost. In addition flexible hydrophones for specialised application in towed arrays are also possible. The TNew Generation' materials have been thoroughly studied in the literature and cover materials such as:

- Piezoelectric Polymers (PVDF, etc.)
- Piezoelectric Ceramics (Lead Titanate, Lead Meta-miobate, Crystallised Glasses, etc)
- ~ Polymer/Piezoelectric Ceramic Composites.

The initial composite work was initiated and recently reviewed by R.E. Newnnam at the Pennsylvania State University, $P(\lambda, \beta^{*})$, where a thorough fundamental imvostigation is continuing. Different, geometric combination of Ceramic/Polymer have been tried by various groups around the world, these are termed connectivities by the Pennsylvania State Workers who pioneered the connect. For a two phase system of Ceramic PET and Polymer, there are ten different connectivities. Evaluation of some new Piezoelectric Composite materials for hydrophone applications have been published by R. Y. Ting $^{(1)}$. in

which five of the ten types of Piezoelectric Polymer Ceramic Composites out of the ten are assessed. Properties are presented in Table I.

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2. PLESSEY AUSTRALIA COMPOSITE

Plessey became active in the manufacture of large components where our expertise in the formulation and fabrication of PRT Ceramics could be utilized. The combination adopted by us is the 1-3 connectivity with ceramic pegs embedded in polymeric phase. In house formulated prezoelectric ceramic and a modified polymer were used to produce the Composite. Volume fraction of PRT ranged from 16-20% with a nominal peg size of 1mm² cross sections.

Comparison of Plessey Composite with other types of composites is shown in Table Two (Private correspondence with N.U.S.C.).

Three Hydrophones designated as P1, P2, 4.P3 were sent overseas to gain an unbiased evaluation of the performance of these Hydrophones. A schematic outline of the Hydrophone is shown in Figure 1.

Two Composite Hydrophones, Pl and Pl were sent to the Naval Research Laboratory, (N.R.L) Underwater Sound Reference Detachment, Orlando, Florida, U.S.A. for testing. Then Pl and Pl were sent to Plessey Marine, Templecombe, (PMT) U.K. who internally arranged for testing with <u>Test Results on Pl, Pl and Pl</u>, the Admiralty Research Establishment, Fortland, U.K.

3. BEAMPATTERNS

Beampatterns were performed at 10 and 11.6 kHz which is near the first mull of the edgefire response. Samples P1 and P2 were tested at N.R.L., Orlando, at 30°C whilst P3 was measured at Plessey Marine (P.M.T.) at about 18°C. These results are shown in Figures 2 & 3. As well P.M.T. measured P3 at 5, 7.5, 9, 15, 20, and 100 kHz. These results are shown in Figure 4.

4. RECEIVER SENSITIVITIES

The open-circuit receiver sensitivities of P1 and P2 were measured at 30° C at N.R.L., with the Hydrophones oriented at 0° (broadside) and 90° and 270° (edgefire).

The results for P1 are shown in Figure 5. P2 and P3 were also tested at P.N.S. and the results are as shown in Figure 5.

5. TEMPERATURE AND PRESSURE DEPENDENCE OF SENSITIVITIES AND CAPACITANCE

The receiver sensitivities and capacitances of the Hydrophones P1 and P2 were measured at U.R.D. at 4°C and 29°C with pressures of 35 kPa. 3.5MPa and 13.8MPa. The results of P1 are shown in Figure 647

6. ACCELERATION SENSITIVITY

Acceleration sensitivity has been measured at $7\,\,\mathrm{M}.0$, on P2 and P3 and typical result is shown in Fig. 8.

EXPLOSIVE SHOCK

Hydrophone P1 has undergone explosive shock testing at N.R.L.

7. DISCUSSION

*

The beampattern results show that the Hydrophones act a a theoretical aperture of their rejor dimension, as the beampatterns show good cartoid shape near the first null. Hydrophone P1 had a fault which manifested itself as a higher dissipation factor and an asymmetric extra lobe on the beampattern at 270° in Figure 3.

The sensitivity results show that at low frequencies the Hydrophones have a flat response. There was a resonance problem with these early Hydrophones that manifested itself as a very well defined resonance at about 6.5 kHz. This problem has since been resolved. The high frequency response is a good approach to the theoretical sink/x behaviour of an aperture as the edgefire response indicates.

The temperature and pressure dependence of the Hydrophones indicates that the design will need some modification if the response is to unaffected by to extreme pressures. The ceramic used is relatively soft Type 2 which could be replaced by the harder types 1 or 3 which would then reduce both the pressure and temperature variations. The fact that the results were reproducible, and that the sample which underwent explosive shock testing survived with no apparent change in performance indicates the physical integrity of the design.

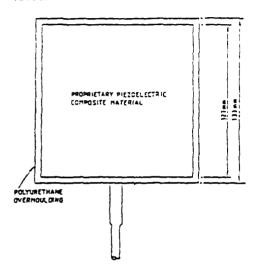
The acceleration sensitivity of the Mydrophone shows strong structural resonance of the mounting plate, however at low frequency it is at least 13 dB and probably >20 dB less than the output level due to fluid loading on the transducer. No special acceleration cancelling features were incorporated into this design, although the work presented here refers to large hydrophones, development is continuing into the production of alternative configurations. Plessey Australia is associated with W.S.R.L in the co-operative development of a small diameter towed array with incorporates flexible hydrophones. Projected performance indicate that the composite may be ideally suited for the towed array in that it may be possible to tailor over a wide range many performance criteria such as sensitivity, acoustic impedance and flexibility.

S. ACRHOWLEDGEHERT

The authors would like to thank Dr. R. Ting of N.R.L. Orlando for testing of P1 and P2 hydrophones. The authors would also like to thank A. Curtis of Plessey Marine U.R. for tests on P2 and P3 hydrophones. The effort by Mr. R. Roberts of A.R.E. is also appreciated.

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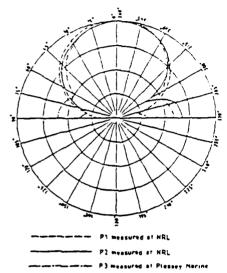
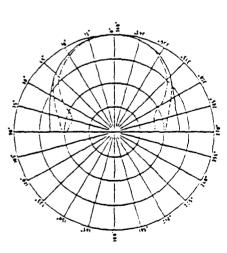


FIGURE 1 - SEAMPATTERNS AT 11-6 KM2

PIGURE 1 - PLESSEY AUSTRALIA COMPOSITE MYDROPHONE OUTLINE



P1 measured at MRL
P2 measured at MRL
P3 measured at Pleasey Marine
SIGURE 2 - 35 AMORTISMS 17 TORMS

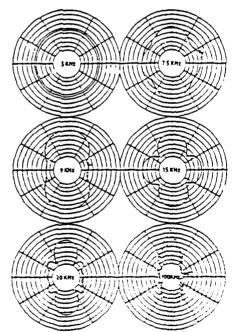
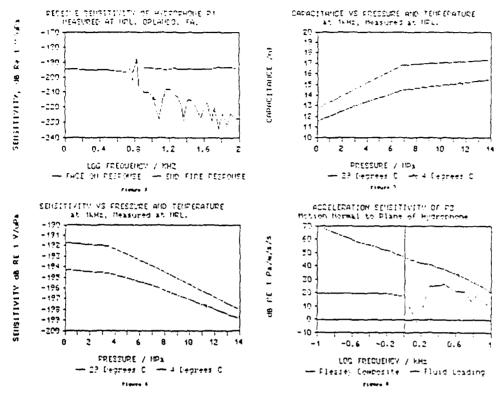


FIGURE CONSCREPANTER OF SOR MEDICAMONE RATHERS, PER AN PROSESSE HAR A



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TABLE :

(TABLE 11 IN PETERENCE 3)

Pieroelectric and Dielectric Properties of Polymery Ceramic Commonities

Sample	<u> 47, 56/87</u>	24: 44-4/41	<u>dha</u> n	ĸ	Dissibation
727-4	43	4	172	1300	0.02
727-5	21	:	42	1690	0.02
3-1 Element	220	72	15.840	<u> 225</u>	معت
3-1 Composite	176	21	2.595	965	0.03
1-1 Composite	13	25	225	59	0.03
J-2 Composite	113	52	7,965	360	2.02
3-3 Composite	. 32	50	1.600	200	a.s :
S-3 Composite	b 12	47	1.034	24	0.26
אים אים אים	10	112	1,120	10	0.21
1-3 0=005178	4 200	:50	20.000	226	0.015

Porous PIT from the Mitzubian Miniming & Cement Corporation, Japan.

⁵⁾ KTM Piezo-Pubber.

S) Data from Reference 3.

di Plossey Australia Pty., Otd.

TABLE 2 HYDROSTATIC MODE PROPERTIES

Property/ Sample	кт 33	(1) Mv dB re V/upa	t um	tan	9h (mVm /N) (H	dhgb 10-12 2/N-1)	Comments
EMI	8.5	- 198.6	600	. 02	195.0	2.90	PVDF
PENNWALT	11.0	- 202.5	750	.02	100.0	1.00	PVDF
EDO	205.0	- 198.0	5000	.007	25.0	1.10	PBTiO3
NGK	38.0	- 197.0	3000	.03	58.0	1.10	Composite
PLESSEY	232.0	- 191.0	3000	.02	94.0	18.00	Composite
BELL LAB	4.3	- 199.0	3000	-	35.0	0.05	Tartaric Acid
BERLINCOURT	295.0	- 194.0	3000	.005	66.0	11.40	Sponge * Ceramic
₽SƯ	98.0	- 194.0	3000	-	69.0	4.10	PZT/Epoxy.
UZG	44.0	- 181.0	3000	-	314.0	38.00	PZT/Foam + Urethane.
JAPAN	183.0	- 181.0	9800	.02	91.0	13.40	Porous Ceramic.
33082A	386.0	- 195.0	2800	.02	64.5	14.20	NRL Porous.
TYPE I	1300.0	- 218.0	3000	.004	4.0	0.20	MIL-STD 1376.
P5N5206	225.0	- 200.0	3000	.006	34.0	2.30	Lead Meta Niobate.

(1) $Mv = g_h^{-\frac{n}{2}}$

* Calculated.

+ Highly pressure dependent.

** Values for STP.

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Department of Ceramic Engineering

12 Formania. Roma Maria (154, 151, 14). Teleropolis (151, 14). LESSESSE RESERVED REC

January 14, 1987

TO:

R. C. Pohanka

Office of Naval Research

and S. Freiman

National Bureau of Standards

FROM:

H. U. Anderson

University of Missouri-Rolla

SUBJECT: Report on Trip to Japan to Attend U.S.: Japan Seminar on

Dielectric and Piezoelectric Ceramics

I arrived at Narita at 5:00 p.m. on November 2, 1986 and was met by T. Tsukamota who escorted me to Yokahama. On Tuesday, November 4, I spent the day at TechnoPatent Services where I presented a lecture and discussed U.S.-Japan patents. These discussions were directed at learning the patent procedures in Japan and how they differed from the U.S. It is apparent that the requirement of the U.S. patent office that the patent must be sufficiently detailed so that someone versed in the field can reproduce the patent is not true for the Japanese patent office. I also learned that a literal translation of a Japanese patent into English loses so much that the important teachings of the patent can be easily lost. In order to make a meaningful translation, the translator must understand the patent so that the correct meaning can be conveyed into English. These are probably the primary reasons that it is so difficult to reproduce the results quoted in Japanese patents.

On the morning of November 5 I traveled to Tsukuba City to visit the Applied Physics Department at Tsukuba University. I presented a lecture there and discussed order-disorder phenomena with Professor Tetsuro Suzuki. Our thermally stimulated current work which was previously sponsored by ONE and some of our subsequent automodulation work on PLZT, BaTiO2 and PMN was of great interest to Professor Suzuki because it indicates that the theories which he and Dr. Wuttig have on the martensitic type transformations may be applicable to nonmetallic solids. We are planning to initiate an interaction between my research group and Suzuki's group in order to further explore this effect. The initial interaction will be to share samples and data.

On November 6 I visited NIRIM in Tsukuba City. My host there was Dr. S. Shirasaki. I presented a seminar there and discussed defect chemistry with Dr. Shirasaki. This was my first visit to NIRIM and I came away very impressed by both the facilities and the personnel. They discussed with me a number of studies that they are doing. In particular, their work on oxygen diffusion in MgO and Al O_3 were of interest. There is a fundamental study in ZnO varistors in which an attempt to understand the grain boundary

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structure is being made. The 10th group is working on optical waveguide materials. They had previously worked mainly on LiNbO $_3$ and LiTaO $_3$, but are concentrating on Ba $_2$ NaNb $_3$ O $_1$ 5 crystals both as films and bulk crystals. The BNN crystals are of interest because they have high transmission efficiency (~75%) and may be useable for pattern drawing in VLSI since they transmit green light well.

I was told that some perovskite oxide preparation techn ques which have been developed at NIRIM are currently being exploited by Japanese industry to make theoretically dense perovskites, but no further information was offered due to secrecy restraints.

I was shown a number of AIN parts which had been made as a result of work at NIRIM. The substrates were translucent. NIRIM is no longer doing work on AIN, but did the initial studies which have lead to important AIN products.

On the evening of November 6 I traveled to Kyoto to visit Murata Manufacturing Co. Dr. Wakino served as an excellent host. I spent November 7 at the Central Research Laboratory of Murata. During my visit I presented a lecture and participated in general discussions on dielectrics. There was particular interest in thin film dielectrics. Y. Sakabe took me on a tour through their research facilities and showed me nearly everything they were doing. There was nothing particularly extraordinary in their facilities, but it was obvious that they are committed to product development and control. The work that Murata is doing in the area of microwave dielectrics is probably their most significant research area. They certainly appear to be the leader in this area.

From November 9 to the 12th I participated in the U.S.:Japan Seminar. I think that Drs. Yamaguchi and Freiman need special commendation for the outstanding facilities and the program format. This was our 3rd seminar and the format of each program has been different. The format of this program was superior to the previous endeavours. I suggest that it be retained. However, some attention must be put to the "roundtable discussions" since improvements are needed there.

The facilities that were provided by YKK were by far the best we have had. I want to express my personal thanks to YKK for the facilities and the hospitality.

I thought the papers presented at the conference were good and probably represented much of the current Japanese activity. The efforts in sputtering and actuators were of particular interest. From my viewpoint Japan definitely leads in these areas.

What did I learn at this meeting?

1) The Japanese have made tremendous strices towards component integration and in the development of sensors and actuators. In my discussions with individuals regarding these activities it is evident that many research organizations are devoting considerable resources to these areas. Japan is the clear leader in these areas. If we are to have any hope of keeping up in these areas our research and developmen activities must be expanded.

- 2) The AIN substrate work which is being done in Japan is first rate and certainly is showing the feasibility of this material for use as a substrate where high heat dissipation is required.
- 3) The Japanese are very interested in all methods for making oxide films. This apparently is a high priority research area since it is important to component integration. The U.S. is still competitive in this area, however we need to expand our efforts if we expect to remain a leader.
- 4) In the area of oxide synthesis, I think that the U.S. is still very competitive. I had several discussions regarding perovskite oxide synthesis which is an area where my research spends considerable time and learned that my knowledge in the field is as good as my Japanese counterparts. However, I must emphasize that the Japanese are moving fast and we will have to expand our efforts and knowledge both in the science of organic-metallic synthesis of oxides and in the implementation of our laboratory knowledge to production if we are to remain a leader.

5) In the area of dielectric materials the level of knowledge of the Japanese and U.S. participants was quite comparable except in the area of microwave dielectrics where Murata is the clear leader. I think the knowledge of the science of dielectric materials in the U.S. is superior to that in Japan, but Japan clearly leads in the area of implementation.

On November 12 I traveled from Toyama to Tokyo. On November 13 I visited with Toshiba Ceramics in Hanada City. There I presented a seminar and toured the research facilities. At this facility I saw the first 8" dia. Si single crystal boule that I have seen. It was very impressive since the puller has incorporated with it a super conducting magnet which provides the field to homogenize the melt. I also saw some very dense AIN substrates and AIN powder. Evidently Toshiba Ceramics is spending considerable effort to produce low oxygen content and sinterable AIN powders.

On November 14 I presented a seminar at Nihin Seiji Keizai Chosakai in Tokyo which is an organization of Japanese businessmen sponsored by the Japan Ministry of Education. In this presentation I discussed the status of high technology ceramics in the U.S.

On November 15 I left Japan and returned home.

I came away from Japan with the same opinion that I had four years ago. We are technically equal or superior to the Japanese, however we fall short in the area of implementing a laboratory concept into a product. I feel that this difference is due to a basic difference in the middle management of companies in the two countries. In the U.S. our managers have to have a product line profitable (<10%) in time periods anywhere from 6 months to 3 years. In Japan they think of product profitability in the 5 to 10 year range. They appear to worry more about market position rather than profits.

I found the Japanese to be much more relaxed than they were four years ago. This was especially true at Murata Manufacturing who were very quick to announce that they were now the number one MLC manufacturer in the U.S.

It is apparent that they feel now that they have won the battle in the U.S. and view their major competition as being Japanese.

I feel that the Japanese have progressed well in the area of component integration, actuators, and sensors. They certainly are the leaders in these areas. We are going to have to hustle in these areas to even keep them in sight.

Thank you very much for the chance to visit Japan. I found it very worthwhile.

Yours truly,

Harlan U. Anderson

HUA/1p

TRIP REPORT: U.S.-Japan Seminar on Dielectric and Piezoelectric Ceramics
November 9-12, 1986, Toyama, Japan

B.A. Auld Edward L. Ginzton Laboratory Stanford University Stanford, California 94305

1. Purpose

These U.S.-Japan seminars are biannual meetings between U.S and Japanese materials and applications scientists and technologists, held alternately in the U.S. and Japan. The 1986 seminar was the third in the series. My responsibilities were to participate in the presentations as an invited speaker, to be present in discussion groups as a lead and panelist, and to be briefed on the research programs at selected Japanese laboratories (in my case, NEC and Hitachi—both in Tokyo)

II. Seminar (November 9-12)

(a) Presentations

The talks and poster sessions were held in the magnificent Conference Center of YKK Company in Korubu City. In the main lecture hall the technological level of the audio-visual facilities was truly awesome, as was the esthetic level of the decor. The organizational structure of the presentations was innovative and efficient.

Two general papers (one American and one Japanese) were given in the first session. These clearly reflected the general tone of the meeting and the distribution of the attendees. The American paper, presented by a professor, was very physics-oriented; the Japanese paper, presented by an industrial technologist, was at a very practical manufacturing level. Mist of the members of the U.S. delegation were from universities, with only a few from industry; in the Japanese delegation the contrary was true. One Australian scientist, with an interest in composites for sensors, was present.

The poster session organization was very original in that each author gave a five minute slide summary of his poster in a joint session, held before each poster display presented in the corridors of the building. This was an excellent idea, but the short verbal presentations were very

mixed in quality. Many of the Japanese presentations were of poor quality, even allowing for the difficulty of speaking in a foreign language. I had the impression that a number of the Japanese authors were there to practice giving talks at an international meeting. The American speakers were generally older and more experienced.

The posters themselves were mainly oriented toward material science (fabrication and characterization of ceramics, where the Japanese excel) At the seminar itself the Japanese attendees appeared to be very open about giving details of their work (processing, etc.). This was also the opinion of my ceramicist colleagues. The same was, however, not the case for one of the subsequent industrial visits. I am not qualified to judge materials-oriented posters; but I gave careful study to those posters dealing with applications. These dealt almost exclusively with simple mechanical devices—actuators, punches, etc. One or two (both U.S. and Japanese) had to do with acoustic transducers. For me, the most useful exposure was to the work on ferroelectric thick film technology by both Japanese and American scientists. I saw several posters dealing with this subject and listened to some lively discussions on the merits of the techniques currently used (sputtering (NEC and Kyoto), sol-gel (U. of Illinois), precursors (Purdue University). This appears to be a technology that will have an impact on acoustic transducers (both conventional and programmablybiased electrostrictors) for signal processing applications.

A striking feature of the attendance list was the absence of scientists and engineers concerned with high-tech device applications (signal processing, imaging, etc.), and this was most pronounced in the American delegation. This question was discussed by the U.S. group at an evaluation meeting at the end of the last day. Attempts had been made to invite scientists from U.S. industry, but most were unsuccessful. The conclusion was that industry felt they would give more information than they received. However, it was very clear from the Japanese presentations that they are very busy developing and commercializing products based on ideas originating in the U.S. and not being developed here. It was the sense of the group that U.S. industry could profit from observing first-hand what is going on in Japan and should be encouraged to send delegates to the next seminar (1988), to be held in the U.S.

(b) Dispussion Groups

I was one of the panel members at the evening roundtable discussion on piezoelectrics. This began with Professor Cross first asking the members of the group to state the topics they wished to see discussed Consistent with my above comments, most of the Japanese proposed very practical questions about the engineering properties of materials and their applications for very well-defined purposes, such as electrostrictors for actuators. There was a very strong interest in composites and ceramics

with anisotropic coupling. A very lively discussion took place on the mechanism for variations in d_{31} and their relation to Poisson's ratio. This was at quite a basic level and involved both the U.S. representatives and the few Japanese representatives from the universities

III. Industrial Visits (November 13 and 14)

(a) NEC

We were received with great hospitality, but the technical information provided about the company's activities was somewhat less detailed than at Hitachi, where we actually visited the laboratories.

In the morning we were given presentations about the organizational structure, were taken to the showroom for a short video presentation and a tour of the product display. We then heard talks on AIN ceramics for cooling chips, multilayer glass ceramics and monolithic multicomponent ceramics, and the ceramic ink-jet head; and, after lunch, talks on diamond-like thin films and low-firing dielectrics. We were able to examine material samples and were given reprints of papers related to the talks, as well as reprints concerning other activities of the company (underwater transducer arrays, ceramic filters, etc.). The day concluded with a presentation by each U.S. visitor of his Toyama Seminar paper

(b) Hitachi

As at NEC, the day began with a general briefing on the laboratory activities and a tour of the exhibition room. This was followed by a series of laboratory presentations by members of Dr. H. Takeuchi's ultrasonics group. These covered the following topics: piezoelectric composites, covering their flexible composites and demonstrating their use in loudspeakers, piezoelectric crystal growth; growth of PhT₁O₂ thin films, covering the details and effects of growth over metal electrodes, ultrasonic microscopy; and sound velocity measurement in biosystems, an ingenious signal processing technique. For the remainder of the afternoon I discussed acoustic waves in solids with a group of engineers, while the rest of the U.S. visitors visited groups doing materials research on LaE₆ and TiS₇.

IV <u>Visit to Sophia University</u> (November 15)

On Saturday, before returning to the U.S., a number of us paid a brief visit to Professor Kenj Uchino to see his research on ceramic electrostrictors and their use in actuators. This was very impressive. First, we had lunch with Uchino, his students and industrial visitors (about 30 people in all). This group spends every Saturday morning

attending a seminar by someone from industry and having technical discussions—an indication of the serious effort the Japanese put into their work. After lunch we visited Uchino's laboratories and collected reprints of his work. Uchino predicts that the electrostrictive actuators will eventually replace solenoids in many industrial applications. This is a prime example of where Japan is developing commercial outlets for materials first researched in the U.S. Uchino gave me a copy of his new book on materials and actuators (in Japanese), a book that sold out its first edition of, possibly, a few thousand copies in three months. It is now in its second edition and he has plans to come out with an English translation. This would be extremely valuable for U.S. industry and should be encouraged.

Third US-Japan Conference on Dielectric and Piezoelectric Materials

Toyama, Japan November 9-12, 1986

Trip Report

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Introduction

Purpose of the trip was to participate in the technical presentations and discussions with the US and Japanese Ceramic scientists, which constituted the Third US-Japan Seminar on Dielectric and Piezoelectric Materials. It was hoped from this close interaction to make a critical evaluation of important trends in the development of these materials. A somewhat more pragmatic objective was to assess the advances in development and manufacturing of "Fine Ceramics" components in Japan.

The meeting was held in Toyama, which was not home to any of the Capanese participants, so that the closer interaction sought was indeed successfully accomplished. Regrettably, it also confirmed that most of the advances in manufacturing and utilization of ceramic dielectric and other state of the art

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ceramic components was taking place in Japan.

Locations visited on the trip included Tokyo (4 days; Hitachi Corp., Science and Technology Agency), Toyama (4 days; size of the US-Japan Conference) and Nagoya (2 days; Narumi China, Japan Fine Ceramics Center and NTK-NGK Spark Plug Co., Ltd.). Assessments of these visits are included in this report. A side visit was subsequently made to China and is reported on in an addendum to this report.

II. Comments/Observations

1. Toyama Conference

The conference presentations were divided into sessions dealing roughly with Dielectric Processing (Session I), Dielectric Properties related to microwave, pyroelectric, mechanical and electrooptic applications (Session II) and Piezoelectric properties and applications (including miscellaneous topics (Session III).

a) Processing

Emphasis in the processing session was primarily on chemical methods for the preparation and characterization of (mainly) BaTiO₃ type perovskite powders. Modifications in composition and processing to permit use of pase metal electrodes (primarily Ni) in multilayer ceramic capacitors is now at the commercial stage. Both Murata and Taiyo Yuden offer these products. Likewise, studies on modification and processing of relaxor type formulations were very much in evidence. Glass-ceramic formulations for use as Cu-cofired substrates for MLC packaging was also a hot topic. This reflects the push for a more integrated packaging concept to achieve higher circuit density and

speed. Asahi glass, Central glass Co., Narumi China; Kyocera, NTK Ceramics and especially NEC are all active in this area.

b. Components

Microwave formulations for resonator and filter applications in the 1-20 GHz range were also featured by Sony, Murata and other companies. Development of microwave ceramic components is an area in which the Japanese have made significant strides, benefiting in many cases from vertical integration with their electronic consumer product lines. Emphasis in the development of the microwave formulations was on high dielectric constant (40-50), high Q and low temperature coefficient materials. Impressive Q values in the range of 8000-20,000 were reported.

Significant emphasis on the preparation of thin film PZT, PLZT and PbTiO₃ components was also noted. Deposition was mainly by magnetron sputtering using various control parameters. For PbTiO₃ this represents a significant advance, in view of the difficulty in preparing PbTiO₃ in any form without cracking. Projected uses for these films are as pyroelectric, piezoelectric or optical sensors and for device applications. Chemical (sol-gel) preparation of these films as in now common in the US (research), was not reported. Incidentally, Ca modified PbTiO₃ formulation (Ichinose-Waseda University) reportedly shows excellent potential for competing with or perhaps replacing LiNbO₃ for sensor applications. Even in the polycrystalline form, its large spontaneous polarization and coupling coefficients make PbTiO₃ an excellent piezo and pyroelectric sensor material. Overall, significant electrooptic use was envisaged for these sputtered films.

c) <u>Piezoelectric Components</u>

Significant activity in polymer PZT composites was reported. This now is

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becoming a commercial product in Japan (Hitachi). Most important, is the recent and widespread development of P2T ceramic actuators. NGK and NEC (as well as others) now offer commercial P2T actuators for a wide range of motor applications. Much of this effort has developed from the pioneering work of Professor Uchino at Tokyo and now Sophia University. He presented a most innovative monomorph actuator based on charge coupled principles. Some interest in actuators based on electrostrictive ceramics was also in evidence as were formulations based on doped BaTiO₃. This emphasis on ceramic actuators and its rapid commercialization surprised the US participants. We have no comparable effort in the US although the technology is well known.

Overall, the quality of the presentations and the technical interactions were excellent. It was noteworthy, however, that the emphasis in the presentations was quite different between the two sides. For the US participants, science and technological developments were the themes, compared to the decidedly product orientation of the Japanese participants. Our net gain, therefore was in seeing how many of the ideas developed in the US (polymer composites, relaxor formulations, thin film dielectrics etc) were being usefully applied in Japan. A topic worth pondering.

Plant Tours

1. Visit to Narumi China, Nagoya Japan

Narumi China is the largest manufacturer of fine china in Japan. This is carried out mainly at their factory in Nagoya. They also have a substantial position in the manufacture of thick film ceramic packages, although only the research and development facilities are located in Nagoya. I was given a tour of the china manufacturing line, which was mainly tableware. The process was substantially automated, but a significant amount of hand labor was required for such operations as attachment of handles and feet (cups, jugs etc.), decorating, inspectin, quality control and shipping. The equipment I saw was impressive and innovative, much of it being produced in the plant. Quality control, at all phases of manufacturing seemed to be a dominant emphasis.

The packaging effort was concentrated in three areas. First the development of screened ${\rm Al}_2{\rm O}_3$ substrates, some multilayer, for routine packaging applications. There did not appear to be any novelty about the materials used, but all operations - screening, firing, trimming, bonding, etc., were carried out in a clean room (Class II) environment and were significantly automated. Most effort was concentrated in this product area. Second, there was a strong effort in the manufacture of multilayer copper cofired packages. Or. Nisnigaki, research manager, was instrumental in this development, which is just now being marketed. The substrate composition is a glass ceramic (${\rm Al}_2{\rm O}_3$ -glass-mullite) which sinters below $1000^{\circ}{\rm C}$ in ${\rm N}_2$ atmosphere. All processing operations were being carried out in a Class I clean environment. I would guess from the eager questions of the engineers that powder dispersion, binder burnout as well as tape casting were operations not fully under control. Finally, some development emphasis in producing AlN,

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SiC and $\mathrm{Si_3N_3}$ substrates was clearly evident. AlN samples were being hot pressed above $1800\,^{\circ}\mathrm{C}$ using in house designed equipment. Most powders were commercially obtained. One gratifying note was that most test equipment used was supplied by Hewlett Packard.

2. NTK Technical Ceramics (NGK Spark Plug Co.) - Nagoya Japan

I did not actually tour this plant since the piezoelectric facility, which I wanted to see, was considered to be "in a very competitive position." I had previously toured the spark plug manufacturing plant in 1982. The sensitivity about the piezoelectric products derive from the fact that NTK is trying to establish a dominant position in piezoelectric stacks for actuators and linear motors, in composites, ultrasonic transducers, knock sensors and a wide range of sensor products. Many of these products require aggressive marketing development. NTK manufacture also a wide range of technical ceramic products including a turbocharger rotor (which is now being marketed) as well as other engine parts from SiC and Si₃N₄. They have a very strong ceramic packaging effort with NEC as a major customer. I also noted a wide range of bioceramics products for use as implants and in prosthetic devices. Dr. Hisao Banno is in charge of the research and technical development effort.

3. Japan Fine Ceramics Center - Nagoya, Japan

Dr. Yoko Suyama (who was trained at MIT) was my host for the visit to the Center. I also met with the Executive Director and the Managing Directors for the Operating Divisions, namely: Administrative Affairs, Information and Public Relations, Education and Consultation as well as for Research, Testing and Development. The Fine Ceramics Center is an ambitious concept which is new even to Japan. The Center as a physical entity is just being completed

(due for occupancy in March, 1987). It consists of a brand new five story edifice which will house well equipped research laboratories, administrative offices, educational and display rooms. Some 50-70 scientists and technical personal will operate the center. Sponsorship is by the central government, local government and well over 200 companies. (I have in my possession a copy of their foundation publication which lists all the sponsors and also contains a first rate write-up on bioceramics development in Japan).

Among the objectives of the Center are: Establishment of a technical data bank with on-line retrieval service; development of procedures for testing and evaluation, leading to standardization; sponsoring of research conferences and seminars, including international cooperation; and, basic research and development in fine ceramic systems. This last function in my view, is an attempt to address the question of the perceived lack of basic research and innovation in the Japanese Ceramic Industry, but in any event there seems to be a serious committment by all parties to the success of the Center. Fine Ceramics has thus been targeted as a major thrust area going into the 21st century.

4. Hitachi Corp. - Tokyo

Hitachi is a very large and diverse corporation, hence our visit was fairly narrowly focussed to microelectronics concerns. Dr. Takeuchi was our host. Much of his previous work has been in piezoelectric materials and it is of significance that he has recently been shifted to the 9th Department, Medical Electronics. There was in fact a strong emphasis on use of ultrasonic techniques for medical diagnosis, using piezoelectric compostes (3-1 in a planar mode) as transducers. Other piezoelectric materials, including sputtered (and epitaxial) PbTiO₃ films were also being used. The medical diagnostic effort seem well advanced and we were shown a number of prototype

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machines. Deposition of ceramic films by sputtering or CVD processes seem to be a major effort of this group. We were told that there was a serious development effort on diamond fims (different group) as a potential device and/or packaging material. Plasma CVD ${\rm TiS}_2$ fils were being deposited (with ${\rm CdI}_2$ structure) for use as electrolyte films in solid state lithium batteries (${\rm Li/Li}_3.6{\rm Si}_0.6{\rm P}_0.4{\rm O}_4/{\rm TiS}_2$). Stoichiometric films with preferred orientation and desirable electrochemical properties were reportedly obtained. Other film work included ZnO sputtered films for transducer application: ${\rm Au/ZnO/Au/fused}$ quartz which was said to have a very high efficiency. We were also shown ${\rm LaB}_6$ crystals produced for electron emitter tip elements. Hitachi has substantial market in this product. As an aside, we were told that a fairly constant 8.1% of sales was ploughed back into research. Again much test vacuum and sputtering equipment, which we saw in the laboratories, was supplied by US companies.

5. Science and Technology Agency - Tokyo

My visit was to the Science and Technology Promotion Bureau (Policy Division) of the Ministry of Science and Technology: my host was Mr. Soichiro Katayama who did his graduate work (Nuclear Materials) at Illinois. In the materials area, the agency is charged with promoting research and development activities in a broad range of materials technologies (high strength, high temperatures, cryogenic, electronic materials etc). It funds ceramics research through the "National Institute for Research in Inorganic Materials" which is concerned with: materials for VLSI fabrication, optoelectronic materials of transparent ceramics, bioceramic materials and synthesis of new inorganic materials. The broad concern of the agency is that basic research be fostered and developed. There was again a concern that Japan is lagging in this area. I could not obtain a budget figure for these activities. A brochure detailing the agency operations is in my possession.

Travel Report of L. C. Burton (EE Dept., VPI&SU) for the 3rd. U.S.-Japan Seminar on Dielectric and Piezoelectric Materials, Toyama, Japan, Nov. 9-14, 1986. (Technical comments only)

Overview Session (Monday morning)

Talks were given by representatives from the U.S. and Japan. Eric Cross first reviewed the history of dielectrics and piezoelectrics. He pointed out the increasing activity in multicomponent structures, multilayer ceramic circuits being an example. I felt that his most important remarks were related to where emphasis should lie in the future. Basically, the pathways of semiconductors should be followed. Much of what has been learned in this field during its extensive development over the past 35 years could be applied to dielectric related systems. This applies across the board: examples pertaining to both semiconductors and dielectrics are single crystal and epitaxial layer growth; precise control of multilayer structures, especially as layers become thinner, with special emphasis on interfaces; definition of small structures; an understanding of the behavior of materials systems, with input from chemistry, materials science, solid state physics and ceramics. Dr. Cross emphasized the future necessity for smaller size, which includes patterning techniques and superlattices. Another example is the epitaxial growth of thin ferroelectric layers. Such layers could potentially be used directly on IC and other chips, removing the necessity for external bypass capacitors.

Dr. Ichinose reviewed the situation in Japan, discussing new ceramic substrate materials, piezoelectric materials, and dielectric materials (capacitors), the latter being subsequently discussed in more detail by Dr. Sakabe. Low firing temperature materials are necessary in order to reduce the need for noble metal electrodes and for compatibility with thick film processing, which occurs at <1000°C. High thermal conductivity materials are necessary, especially in the

future as multilayer component densities increase, for increased power hybrid applications, for laser heat sinking, and for microwave applications since power generation increases with frequency. Dr. Ichinose made reference to the following materials which could satisfy some of those needs: SiC-BeO, AlN and CVD diamond films.

Dr. Sakabe then discussed new capacitor materials. They have a Pb-based Y5V type with K=24,000 (I assume this is at Murata). He also emphasized the need for thinner layers (to below $10\mu m$?) and the need for lower firing temperature materials.

Poster Sessions

I felt that the four minute summary presentations that preceded the poster sessions were on the whole, very good, and recommend this format in the future.

(It would be an improvement if only a summary of objectives and results were given; some speakers tried to present their entire papers.)

Of particular interest in Monday's session was some of the new fabrication work. An example is the sol-gel processing of PLZT dielectrics reported by D. Payne, with K up to around 2000. This is certainly an attractive technique (spin coating) for forming thin dielectric layers, with firing temperatures (<700°C) that are compatible with ceramic, thick film, Si and GaAs technologies.

Base metal electrode work was reported by Murata, Kyocera and Taiyo-Yuden. The Japanese seem to be working more heavily in this area than the U.S. This could be important in development of lower cost electrodes compatible with lower firing temperature dielectrics.

Our paper "Conduction Mechanisms in $BaTiO_3$ Based Ceramic" was summarized in a four minute presentation and presented at the poster session.

I had several discussions with Y. Sakabe of Murata concerning capacitor degradation mechanisms. They have been doing some work that parallels our own.

We discussed the concept of a "virtual cathode", which could potentially exist in

any n-type oxygen deficient oxide dielectric. Oxygen diffuses away from the cathode resulting in an adjacent lower resistance layer. This process can be apparently reversed, by reversing polarity, as we have shown. He agreed that this was a likely mechanism, but details still have to be worked out. Is the oxygen ion motion mainly through grain boundaries or bulk? How uniform is the thickness of the reduced layer? What changes are occurring in the rest of the dielectric? We agreed to continue discussing these questions, and he plans to send over samples for us to measure.

During Tuesday's poster session, it was obvious that the Japanese are doing alot of work in the microwave dielectric area. The U.S. had no papers in this area. The Japanese also reported work in an area where we do not seem to have alot of activity, that of sputtered dielectrics. The work reported by Kyoto University and Waseda University shows good progress toward deposition of thin films (<lumn thickness) of PZT and PT.

On Wednesday, the work reported by Kahn of MRL and Banno of NGK Spark Plug Co. both dealt with the effects of controlled pores on piezoelectric and other properties. This is of interest not only in the context of piezoelectrics, but more generally, relative to porosity in dielectrics, including intentionally porous materials for low K, low firing temperature tape, and thick films. An interesting question is whether or not electrical reliability is inherently degraded by pores, or if it is determined more by ambient. It seems reasonable that high voltage material would be degraded due to electric field enhancement and partial breakdown, but the issue is not as clear for low voltage applications (<1V/µm).

At the wrapup session on Wed. afternoon, it was agreed that the Seminar was useful and should be continued. However, there was some concern expressed about the small number of U.S. companies participating in the meeting.

Industrial Tours - NEC

On Thursday, six of us visited NEC (Nippon Electric Co.) NEC is doing alot in

semiconductor devices, VLSI, electronic materials and ceramic, including III-IV compounds, ultra-fine line generation and thin films.

Four areas of work were noted in their Materials Research Lab: Electronic Ceramics (including dielectric ceramics, low fire MLC, peizoelectrics, ML actuator, semiconducting ceramic and MLC varistor); Ultra-fine powders; Thin films (mainly carbon-like and ferroelectric); Metals (rapid-quenched, superconducting).

We then heard several seminars from NEC staff. Y. Kurokawa discussed AlN ceramics. This is being studied as a high thermal conductivity substrate. They have a huge MBE system, custom built (estimated cost \$1M), and a similar sputtering system. They can grow multilayer AIN substrates resulting from the reaction $2Al + 2NH_3 \longrightarrow 2AlN + 3H_2$. Thermograms were shown for a Si chip on an AlN substrate, and compared to a similar chip on Al_2O_3 . The former indicated a maximum temperature of $43O_5$, the latter $65O_5$. They also plan to use the AlN as a substrate for LED and laser diode chips.

K. Utsumi then discussed MGC (multilayer glass-ceramic) and MMC (monolithic multicomponent ceramic) substrate work. The MGC is composed of 55 wt. % $\rm Al_2O_3$ and 45% Pb borosilicate glass) fired at 850-950°C. They use Au or Ag/Pd as the conductor. They obtain high insulation resistance (~ $3 \times 10^{14} \ \Omega$ -cm) and current less than 1µA at 50V bias. (This material appears somewhat similar to DuPonts' low temperature green tape).

Their via capability is impressive: 110,000 vias 80µm dia. on several cm² of sheet. They use RuO₂ resistors for hybrids, sintered at 900°C, and have buried MLC capacitors, using both low K and high K layers, all with a single firing. So the result is an MLC system used as a substrate for a hybrid circuit, which contains the resistors, capacitors and conductors. I was very much impressed by this presentation. They appear to be substantially ahead of us in multi-component MLC technology.

Next Dr. Suga discussed the ceramic ink jet head. Ink jet nozzles are formed in a multi-layer structure using patterns formed photolithographically. The ink

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ejection from the nozzles is controlled by actuating piezoelectric drivers, whose electrodes are buried in the multilayer.

Dr. Showata discussed diamond-like thin films. He reviewed methods used for forming such films (thermal decomposition, ion beam, direct sputtering, and CVD using DC, RF or microwave power). They use the DC approach in a rather simple diffusion pumped system. Films are amorphous when deposited at room temperature, on a Si substrate. Their thermal conductivity increases to about 400 when annealed at 400° C (compared to the diamond literature value of 2000 W/mK).

M. Yonezawa then discussed low firing temp. dielectrics, specifically a Pb-based ($PbTiO_3 + PbZrO_3$) composition used for X7R type MLC capacitors.

Each of the U.S. people then presented seminars on their own work. We then saw their "Show Room" exhibit, a very well put together exhibit of R&D areas on posters and in glass cases.

One apparent advantage of the overall organization of NEC (and of Hitachi, which we visited on Fri.) is that their dielectric and ceramic related work can draw from, and even work jointly with, the semiconductor related groups at the same company. Work on development of say new substrates for high power chips or multilayer substrates for active hybrid circuits can be coordinated between the chip people and the substrate people, in a more efficient fashion than if chips and substrates are made by different companies.

Hitachi

On Friday five of us took a tour of Hitachi's Central Research Lab. Here we visited several labs and heard the technical presentations in those labs.

C. Nakaya and Y. Ito discussed their work on peizoelectric composites and crystals. K. Kushida discussed the growth of PbTiO₃ thin films, by sputtering, onto a single crystal which had been previously covered with metal contact fingers. As the films grow, they cover over the contacts and coalesce into quite large crystallites.

H. Kanda discussed his ultrasonic microscope which has a depth damage resolution of about $5\mu m$. T. Ogawa discussed sound velocity measurements in biosystems. He indicated a 2-dimensional capability at present, with plans to expand to 3-dimensions. This system has been used to map sound velocity in biological tissue, and has demonstrated success at locating damaged regions in human organs.

The growth of LaB₆ single crystals was discussed in the lab of T. Aida. (LaB₆ is used as electron emitter in SEM machines because of its low work function.) We saw the molten zone facility where crystals are grown at 2700° C.

The final presentation was by K. Kanehori who discussed the growth of TiS_2 films for thin film batteries. These are quite thick films (30-60µm) deposited by CVD following the reaction x Li + $TiS_2 \iff Li_xTiS_2$

Again, Hitachi is obviously a very diversified company. In such a situation, semiconductor and dielectric (and other) groups can interact when necessary if a product involving both disciplines is to be developed. It would be interesting to know how many US companies are diversified to the point, and have internal communications that are good enough, for such coordinated product development to occur. NEC and Hitachi both appeared impressive in this regard.

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TRIP REPORT
TOYAMA, JAPAN
November 9-12, 1986

Stephen W. Freiman Ceramics Division National Bureau of Standards Gaithersburg, MD

The purpose of this trip was to act as the U.S. chairman and to paticipate as a speaker in the Third U.S.-Japan Seminar on Dielectric and Piezoelectric Materials. The seminar was held in a hotel near Toyama, Japan. In arranging this meeting, it was agreed between professor Takashi Yamaguchi, the Japanese chairman, myself and other members of the U.S. organizing committee, Dr. Robert Pohanka and Dr. David Payne, that in order to maximize real communications between participants, it would be best if almost all of the papers were presented in poster form. In addition, each speaker was given four minutes to summarize his presentation at a session held before the posters were viewed. This arrangement turned out to be an excellent format and gave rise to extensive individual discussions.

There were approximately 25 U.S. participants and 60 Japanese. This ratio is reasonable considering that Japan was the host country. What is of concern, however, is the fact that about three quarters of the Japanese participants were from industry, as opposed to universities or government laboratories, compared to only one quarter from U.S. industry. For instance, there were no U.S. capacitor manufacturers represented at the seminar even though invitations had been issued to them. Other companies turned down invitations as well, a number citing financial reasons for not attending.

Since the first U.S.-Japan Seminar, held four years ago in Tokyo, the discussions between the U.S. and Japanese participants have become more open. I believe that this openness is a direct result of the fact that essentially the same core of people have been attending these meetings. We have gotten to know our counterparts in the other country, and feel more comfortable in discussing the details of our research. Much of what was learned came about during more informal talks rather than at the sessions.

From a technical point of view, the Japanese appear to be taking an increasing interest in mechanical properties, not just of structural ceramics, but of dielectric and piezoelectric raterials as well. I see an expanding effort in relating the fracture behavior of these materials to chemistry and microstructure. They have recognized the need to be able to predict the relability of ceramic devices such as switches and motors based upon fracture mechanics concepts. At present the Japanese rely heavily on work performed in the U.S., but their efforts in fracture mechanics research is increasing. There are

programs at Sophia University, the University of Tokyo, and the Japanese National Defense Academy directed at understanding the mechanical properties of piezoelectric ceramics.

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In particular, a number of the Japanese participants were concerned about the selection of an optimum technique which can be used to determine the critical fracture toughness, K_{IC} , of dielectric or piezoelectric materials. There was discussion on a number of topics involving specific aspects of the use of these ceramics. For instance, it appears that the alignment of the domains in a piezoelectric ceramic in the process known as poling, has a measurable effect on crack propagation. In a study at the University of Tokyo, cracks were observed to propagate more readily in the direction of poling than in the perpendicular direction. Another area of discussion involved the possible effects of cyclic, as opposed to static, loading on crack growth in components such as electrostrictive and photostrictive actuators for servovalves and photostrictive relays. Professor Uchino at Sophia University is currently investigating the mechanical reliability of electro-optic devices which undergo complex stress states in service. Although there is some work going on in the fracture of multilayer capacitors in Japan, it seems confined to the determination of fracture mechanics parameters, rather than being a research effort. There was one paper presented at the meeting, however, discussing the relationship between mechanical and dielectric failure of barium titanate ceramics.

A meeting of the U.S. participants was held at the close of the Seminar in which our views of various aspects of the technology could be summarized. Based upon these discussions, it was decided that the Japanese are clearly ahead of us in the areas of microwave dielectrics, actuators and motors, thin film ferroelectrics, and low fire dielectrics. While the U.S. has a greater knowledge of materials such as relaxor ferroelectrics, we are not making commercial use of this knowledge. In general the work discussed by the Japanese was of a more practical nature than the U.S. work. One participant was of the opinion that they were more open in their discussions than the U.S. One of the major topics of discussion at this meeting was how to generate more participation by U.S. industry. One way in which we will attempt to do this is to eliminate the series of post-seminar tours. It was thought that many companies did not come to Japan because of the possible obligation of hosting the Japanese in their plant at the next Seminar to be held in the U.S. in 1988. The preliminary plan is that I will be U.S. Chairman of the Seminar again in 1988, and that the meeting site will be the National Bureau of Standards. The format for the Seminar will remain essentially the same, with most presentations being given in the form of posters. These plans will be discussed with the incoming Japanese Chairman in the next couple of menths.

THE THIRD U.S.: JAPAN SEMINAR ON DIELECTRIC AND

PIEZOELECTRIC CERAMICS, AND RELATED LABORATORY VISITS

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NOVEMBER 8-17, 1986

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Martin P. Harmer

Department of Materials Science and Engineering

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THE THIRD U.S.:JAPAN SEMINAR ON DIELECTRIC AND PIEZOELECTRIC CERAMICS, AND RELATED LABORATORY VISITS NOVEMBER 8-17, 1986

The workshop provided an excellent forum for updating the U.S. and Japanese participants on recent developments and trends in the field of dielectric and piezoelectric ceramics. The laboratory visits provided an excellent opportunity to witness the workings of the Japanese electronic ceramics industry first hand. I visited the capacitor manufacturing division of Murata and the research laboratory of NEC. Frankly, I found the Japanese industrial participants to be more open about their research and manufacturing technology than I had expected. Murata showed us every aspect of their capacitor manufacturing process. NEC presented us with a detailed summary of their current research and development activities. The representation from industry and academia was significantly imbalanced amongst the two U.S. and Japanese delegations. The great majority of the U.S. delegates were from universities whereas the Japanese delegates were overwhelmingly from industry.

I list the following areas that I sensed the Japanese have developed an edge over the U.S. These are areas where the U.S. may need to catch up:

(1) actuators and piezoelectric motors

A Japanese authority in this field is Dr. Kenji Uchino in the Department of Physics, Sophia University, Kioi-cho 7-1, Chiyoda-ku, Tokwo

102. NEC is working very actively in this area developing multilayer piezoelectric actuators to be used in ink jet printing heads. Relaxor materials (lead magnesium niobate $Pb(Mg_{1/3}Nb_{2/3})0_3$ in particular) are strong candidates for electrostrictive actuator applications. For a good review on actuators see the article by Kenji Uchino entitled "Electrostrictive Actuators: Materials and Applications" pp647-652 in Bull. Am. Ceram. Soc., Vol 65, No 4 (1986).

(2) thin film sputtering

Several of the Japanese papers presented at the workshop demonstrated the feasibility of sputter depositing epitaxial thin films of PLZT, PZT and PT onto a variety of substrates including silicon, platinum, sapphire and magnesium aluminate spinel. The ferroelectric and pyroelectric properties of the thin films look very promising. NEC has a group studying thin film sputtering of barium titanate and lead-based dielectrics as well as metals. NEC has been successful in producing sputter deposited artificial superstructures of Mo and Ni (5 monolayers of Mo codeposited with 5 atomic layers of Ni). An exciting area that this suggests for future research is the development of artificial superstructures of ceramic dielectrics/ferroelectrics.

(3) microwave dielectrics and pyroelectrics

It was noticable that only Japanese delegates and no U.S. representatives contributed papers on either of these topics at the seminar. Complex perovskites such as $Ba(Mg_{1/3}Ta_{2/3})0_3$ are being actively developed as microwave resonators at the Murata Manufacturing Co.,Ltd. in

Japan. Dr's. Wakino, Tamura and coworkers at Murata are working in this area. They have been very successful in using far infrared spectroscopy for correlating lattice vibrational modes with crystal structure and B-site cation ordering. We plan to collaborate with Dr. Wakino in this area since their infrared techniques are very complimentary to our microstructural and defect chemistry work on relaxor type dielectrics for microwave applications. Nishigaki et al. (Naruma Technical Laboratory, Nagoya) presented an interesting paper on the microwave properties of BaO-TiO₂-WO₃ ceramics. A second phase (BaWO₄) with a negative T_f was used to produce microwave ceramics with a near zero T_f .

(4) thermally conducting substrates and integrated packages

Japan seems to be quite far ahead in the development of thermally conducting substrates, especially of aluminum nitride. NEC showed us translucent aluminum nitride substrates that were reported to have a thermal conductivity as high as $240\text{-}260~\text{Wm}^{-1}\text{K}^{-1}$ which is very close to the theoretical maximum of $320~\text{Wm}^{-1}\text{K}^{-1}$. NEC uses powders made by Tokuyama Soda and sinters or hot presses at $2000\,^{\circ}\text{C}$ using CaC_2 as a sintering aid. NEC has also been the first to develop integrated cofired multilayer packages containing mixed layers of capacitors (lead-based relaxors) and resistors in with the conventional insulation/conduction layers. NEC has made structures with 41 layers cofirable in air for modules containing 36 chips. NEC is also working on producing amorphous carbon films with diamond like properties using CVD technology (CH4-H2) depositing on silicon.

(5) clean room manufacturing

It was very impressive at Murata to see capacitor mass production carried out under Class 10,000 clean room conditions. Murata claimed to see a dramatic improvement in product reliability and reject losses after converting to clean room manufacturing.

In summary, this meeting was an outstanding opportunity to become acquainted and exchange ideas with our Japanese counterparts. I found it to be very rewarding. It was very well organized and special commendations go to the cochairmen, Dr. Freiman and Professor Yamaguchi for their outstanding organization and to Dr. Pohanka and the Office of Naval Research for their support in making these seminars possible.

REPORT ON TRIP TO JAPAN November 6 - November 18, 1986¹

M. Kahn Naval Research Laboratory Code 6363

The following report contains the Publication Release Request copy of:

- 1) Reviews of many of the papers presented at the Third, ONR sponsored U.S.-Japan Seminar on Dielectrics and on Piezoelectric Ceramics in Toyama, Japan, Nov. 9-12, 1986 as well as some information presented during laboratory visits.
- 2) Some notes from the panel meeting on piezoelectrics at the same seminar.
- 3) Some discussion of Dr. Yamagida's programs at the University of Tokyo.
- 4) My impressions from visits at the Sony Central Laboratories, at NGK and at some of the TDK ceramic capacitor operations in Akita.

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 - f. Microwave Materials
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 - H. Relaxors and Piezoelectric Materials
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- IV. Visit to Tokyo University
- V. Plant Visits
- VI. Summary
- VII. Art Buchwald's comments on the subject

I. Introductory Remarks

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- 1) In his keynote address E. Cross proposed that unique and useful phenomena will be derived through investigating and optimizing ferroelectric behavior in extremely thin and small regions, following the example of semiconductor technology. Scaling down to "micro" and "nano" subdomain microstructures is presently not adequately understood but contrary to present interpretations, polar micro regions may well be possible. "Normal" ceramic surfaces are thought to be highly disordered, but with the advent of technologies such as vapor phase CVD, the implementation of atomic order on surfaces can well lead to the verification of very short range ferroelectric phenomena. 200-1000 Angstrom ferroelectric nanocomposites may then become feasible. Artificial super-lattice structures could then stabilize metastable configurations with shallow potential atomic energy wells. This could give large atomic displacements, providing high pyro and piezoelectric sensitivities and even positioners with atomic accuracy.
- 2) Ichenosi from Waseida University discussed the efforts of four manufacturers to develop and market lead silicate borate glass, filled with 30-60% of alumina as thermal substrate material, similar to what is being worked on by Dupont in the United States. Maximum density is attained between 800 and 900°C. He also described the well-known silicon carbide beryllium oxide doped substrate material (pioneered and publicized by Hitachi at least 2 years ago) as well a pressureless sintered, aluminum nitride composition, marketed under the name of Super Shapal by Toyo soda. This material is almost 85% translucent to visible light and transparent to infrared. Reduction of the oxygen content of both silicon carbide and aluminum nitride powders to significantly below 1% is thought to be the cause for significantly enhanced thermal conductances.

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He mentioned work on diamond CVD coating and also showed a number of schematics of piezoelectric ultrasonic motors, both utilizing stationary as well as propagating waves. He also showed a design that used a magnet to couple piezoelectric motion into a rotor. Efficiencies of 80% were quoted.

3) Sakabe (Murata) presented a review of the properties of low fired, stable K materials and of relaxor based dielectrics that contain ZnO. The materials he discussed are utilized in Japan in large scale production, including in multilayer capacitors with nickel electrodes having capacities up to 400 micro farads, that are made at a rate of up to 20 million capacitors per week.

Murata are also making strontium titanate internal boundary layer capacitors and are reporting effective dielectric constants to 200,000. This is attained by making an ohmic, rather than a junction contact to the ceramic. This is implemented by indiffusion of aluminum. No advanced techniques to analyze the behavior of such devices (as for instance cole-cole plots) were shown. In closing he mentioned that they are conducting a substantial effort in 10 gHz dielectric resonators for applications in direct broadcast satellite receivers. Q's above 8,000 at 10 GHz with very low temperature coefficients are attained. Results giving even higher experimental Q values are discussed below. Their basic thrust is to obtain higher dielectric constants to lower resonator size without a significant reduction in the high frequency Q.

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II. Contributed Papers (both at the symposium as well as presented during laboratory visits).

A. Electronic Films

It appears that the preparation of single crystal or of ferroelectric thin films is presently one of the most advanced areas of electronic materials research. Japanese researchers reported primarily on the utilization of sophisticated instrumental film forming methods, whereas applications of

chemistry (i.e. sol gel and organometallics) were reported on by U.S. workers.

- 1) Matsubara (NEC) reported on the CVD deposition of MgAl₂04 epitaxial films on top of N type single xtal silicon wafers. Onto these they R.F. magnetron sputtered PLZT films which again grew epitaxially on top of the MgAl₂04 substrate layer. The films showed single crystal structure, using Reflection High Energy Electron Diffraction (Rheed). The lattice constants varied with the lanthanum content. The sophistication of this work is substantial.
- 2) Wasa (Matsuchita) discusses results from magnetron sputtering of PLZT onto sapphire substrates. His films were polycrystalline and showed a maximum dielectric constant of about 500 with 10% lanthanum. Changes in deposited stoichiometry due to the high substrate temperatures (500-700°C) were mentioned.
- 2) Tamura at Sony Labs showed me yittrium garnet films grown by liquid phase epitaxy on top of a gadolinium gallium garnet substrate. Tunable filters were built out of these and grooves in their surfaces were said to almost eliminate higher order responses. The films were said to find use in variable, high frequency osscillators in communications equipment. At the same time I was also shown the operation of a magnetic bubble memory in which bubbles were moved from one location to another and also obliterated, all using an argon laser beam. The preferred locations for the bubbles were generated in liquid phase epitaxially grown yittrium garnet films by etching small square depressions into the surface of such films. The introduction of bismuth into this garnet provided it with a high Faraday rotation angle. This permitted optical readout of the state of the memory.
- 4) Murata workers discussed a metallorganic CVD technique for the deposition of tantalum oxide films. Dielectric constants of 26, with 4-6 megavolt per

centimeter capability in a 100 Angstrom thickness were mentioned. Tantalum ethylide Ta(OC2H5)3 vapor was used in the presence of titanium O(C3H7)4 vapors, with the titania providing an acceptor in the tantalum oxide structure. Substrate temperatures above 650°C caused film crystallization, but the dielectric strengths of the lower temperature amorphous films was said to be higher than of those that had been crystallized.

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- 5) R. Vest reported on ferroelectrics from metallorganic precursors: Defect free lead titanate and lead strontium titanate films, covering 2 cm by 2 cm areas with near theoretical density were reported. He indicated that fast drying is necessary in these materials to obtain precipitation from the liquid without prior gel formation. They have to be made thin so as to prevent cracking from drying shrinkage. Multiple, superimposed film applications are possible.
- 6) D. Payne discussed spinned-on and fired lead titanate alkoxide based films that he had made: Metal etoxide solutions were spin cast on smooth substrates and densified at 700°C. High quality ferroelectric properties were shown in 1 micrometer thin films. This demonstrates a high degree of order and crystallization after firing at relatively low temperatures. The films were said to withstand 100 volts per micrometer and this was said to permit their application as memory devices.

B) Processing

One of the more intriguing presentations at the seminar was by Shiosaki on laser activated grain boundary etching. More conventionally, there were some interesting analyses of surface chemistry phenomenae and their effects on dispersion and packing.

1) Shiosaki from Kyoto University told of a novel ceramic drilling technique.

A KOH solution covering a PZT ceramic is excited by a laser and whole grains

are removed in the irradiated area. The progression rate with a 1 watt laser is more than 100 micrometers per second. It does not appear that there is damage in the ceramic constituting the walls of the hole. X-ray diffraction of the residue verified that whole grains had been removed out of the ceramic. A variety of ceramic formulations have been successfully drilled, using a self imaging focusing mechanism. The latter derived its input from the acoustic noise generated during laser irradiation in a PZT plate that supports the sample. The hole drilled is not fully cyclindrical but a clean pattern can be generated.

2) Hirano (Univ. of Nagoya) reported on the synthesis of a 0.3 micrometer size mono-dispersed and mono-sized spherical particle suspension of zirconium titanium stannate, derived from alkoxides. These materials had been sintered in the past only with the help of sintering additives as zinc, nickel, iron or lanthanum oxides. They have desirable 10 GHz properties for applications in direct broadcast satellite receivers and telecommunications. Hirano's work on these materials was intended to make fine powders that could be sintered without sintering aids and hopefully thereby attain higer Q values.

He liquid mixed alkoxide derived precursors and a partial description is given of rather critical hydrolysis and multiple refluxing conditions that gave mono sized and mono dispersed spherical particles of the desired compositions. No small feat. The particles were dried by filtering on an 0.01 micro meter filter (made by the Toyo Rashi Company Ltd. in Tokyo) and fired to relative densities of >96% with Q values up to 5300 at 10 gHz, without any sintering aids. He felt that the application of high compacting pressures to deagglomerate fine particles can be counter productive, as it introduces strains in the material that give rise to excessive grain growth. The latter has been shown conclusively for hot pressed materials. The

application of zeta potential titrations and or other measurements indicate to him, that base acid surface reactions are not as reversible as is often assumed: For instance H⁺ atoms that are attached to a bismuth oxide surface during acid treatment, are not replaced by OH molecules in a basic environment, but remain there and form "complexes" with OHs on adjacent sides. This model may be somewhat approximate, but evidence pointing to nonreversability of surface reactions has been observed elsewhere. This may well be the reason that most practical dispersant systems are of a steric nature, relying on a polymer rather than just on the surface charge for dispersion. The nonreversibility of surface reactions makes it necessary to control the electro chemical environment (i.e. the optimum pH level, as established by previous zeta potential titrations) right from the time a powder is originally synthesized through all stages of processing. This then permits purely electro-static repulsion to dominate and provide complete dispersion, negating the need for steric dispersion polymers.

3) Ueyama from Hitachi showed a linear increase in packing density of both alumina and barium titanate particles as agglomerate size is reduced. The theoretical green density calculated from mono size 8 coordinated spheres is obtained as agglomerates are eliminated. The primary particle size is then measured. The same mono size particles show a small decrease in packing density when the concentration of PMMA binder is reduced from the minimum void volume (approximately 12%) to lower values. The group at Hitachi also investigated the effect of agglomerate size and binder concentration on the sintered density of barium titanate. They found that elimination of agglomerates gave lower temperatures of surface densification. Agglomerate free barium titanate attained its final density of 5.8 gram/cm³ at the surface

densification temperature, independent of binder concentration or of green packing density.

- 4) L. Levinson presented results from GE's laser patterning interconnecting work, pertaining to the optimum composition of the polymer that carries the wiring. This is to adjust its absorption coefficient for the laser light so as to maximize the etch rate. A peak in the etch depth per pulse versus absorption coefficient curve was found.
- C. Barium Titanate Analysis and Dielectric Compositions
- 1) D. Smyth showed that the site occupation preference of tri-valent impurities in barium titanate depends both on ionic size as well as on the stoichiometery of the matrix. Yttrium and Erbium have the most intermediate ionic size and they show a variable site occupation preference, most strongly determined by the stoichiometry of the matrix. He showed some self compensation when barium titanate is doped with yittrium. This is indicated when the valley in the resistivity versus dopant concentration curve is shifted to significantly higher concentrations, also causing the curve itself to be significantly broader. On the other hand the full, theoretically expected self compensation due to simultaneous occupancy of both the A and B sites is only rarely observed. Simple and elegant.
- 2) R. Buchanan reported that the addition of zirconia to barium titanate gave (after firing below 1300°C) grain growth inhibited ceramic with the zirconia at the grain boundaries. At higher temperatures grains grew and zirconia was found in the lattice. The addition of calcium alumina borate flux gave sintering temperatures below 1175°C. Fluxing was said to allow diffusion of zirconia. He observed a Curie point shift, without grain growth above 1 pm. Evidence of boron in the grain bulk under these conditions was also claimed.

- 3) I. Burn discussed a low fire K 10,000 Z5U formulation, that is said to be precalcined with a small amount of lead. It was said not to contain additions of bismuth, cadmium fluoride or other volatiles. His results are achieved through close control of A-B stoichiometry and a close donor-acceptor balance. Conduction is said to be electronic. He uses a new submicron barium titanate powder and the system is fired at 1100°C. 70% silver electrodes are used.
- 4) Takabatake from the Asahi Glass Company reported on glassy films having a dielectric constant of 6.5 at at 100 KHz. They are intended to provide a low temperature firing multilayer technology for hybrid circuits. The glass-ceramic contains alumina, that does not react at 900°C. 2 MgO SiO2 is added to this. When it dissolves, it causes the boron in the glass to react with the alumina, giving the glass a high resistance to corrosion by water. A similar system has been commercially sold in the United States for a considerable period.
- 5) Abe from Sakai Chemical prepared barium titanate powder using hydrothermal synthesis. The desired 1000°C sintering temperature was achieved through doping with additives.
- D. Dielectrics for Nickel Electrode Multilayer Capacitors

The volume of nickel electrode multilayer capacitors made in quality conscious Japan tends to contradict U.S. claims that such devices cannot be made reliably. The history of this product (mentioned below) should certainly set one to think.

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1) The paper by Sakabe from Murata on barium titanate based capacitors with internal nickel electrodes is a case of superior Japanese engineering in the application of U.S. science. One of his composition appears to be an acceptor doped, slightly barium rich, 10% calcium containing Z50 material, very similar

to that put together and patented by Smyth and Error in the late 60's. Murata got a patent (in 1976) on the calcium addition and the function and site occupancy of their 10% calcium addition has been described by Don Smyth. Murata fires at relatively low oxygen pressures (10-11 ATM PO2) to prevent loss of capacitance control due to nickel oxide diffusion. The significant part about all of this is that at least 3 U.S. multilayer capacitor manufacturers tried to introduce nickel electrode capacitors into the U.S. market. Their lack of success has to be at least in part attributed to an insufficient willingness to make the required investment in engineering the system. This resulted in the premature marketing of devices that had inadequate life test performance. It appears that Japanese perserverance led in this case to a new product, i.e. to what they claim are economical and reliable substitutes for 1 to 100 mf tantalum capacitors.

Sakabe also mentioned a set of NPO and X7R formulations that are compatible with nickel electrodes. Again, a lot of early work was also done on these in the U.S.

2) Kishi from the Tayo Yuden Central Research Laboratory added 3% of an unspecified, akaline earth containing lithium silicate glass to 1220°C solid state reacted barium titanate powder. It acted as a low temperature flux, lowering the sintering temperature to below 1200°C and also provided acceptor doping to the matrix. "Reliable" nickel electrode multilayer capacitors are presumably made from this. Both Z5U as well as X7R behavior are described. No post calcining milling is mentioned. This appears to be a rather ingeneous system.

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3) Fujikawa reported on X7R nickel electrode multilayer capacitors containing $CaZrO_3$, Y_2O_3 and $\sim 0.5\%$ MnO.

E. Capacitor Reliability

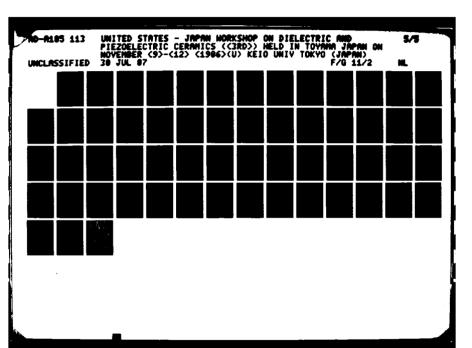
Three U.S. papers on this subject illustrate the present U.S. concern and ONR sponsorship of this subject. It should be noted though that the first paper I ever saw discussing cracks leading to low voltage failures (blaming chlorine from CCl4 degreasing fluid) came from Japan and also that at least TDK is doing in-house work on understanding delaminations (see below).

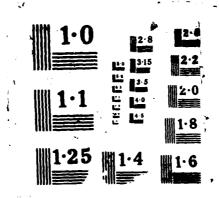
1) H. Anderson subjected multilayer capacitors to a 7700 temperature gradient, whereupon they developed interelectrode cracks. These were then subjected to voltage and temperature testing. The currents he observed were strictly related to the presence of humidity and to voltages above .5 volts. Lower voltages or the elimination of humidity (either by heating or by drying) resulted in low currents. He therefore concluded that electrolytic conduction is responsible for "low voltage failures" since high voltages could dry out the cracks. No phenomena that could be related to the growth of metallic dendrites was observed.

- 2) L.C. Burton showed a conductivity peak in BaTiO3 in the Ohmic (low voltage) regime, near the cubic to tetragonal inversion temperature.
- 3) J.P. Dougherty calculated the heat rise in a typical rultilayer capaciton due to hysteresis losses from AC voltages. He finds that 12 volts ms can heat a typical capacitor chip at >30°C per second up to 130-140°C. In a cold ambient this was said to develop stresses up to 400 kilogram meter within 10 seconds.

F. Microwave Materia's

The Japanese developments described in this section are a direct outcome of an initiative by the Japanese government, i.e. the previously noted installation of satellites for direct proadcast TV. These materials transcend





earlier U.S. developed microwave dielectrics, both in time as well as in performance.

1) Tamura (Murata) reported on Ba(Mg1/3 Ta2/3) 03 that develops a high Q due to MgTa ordering, and the subsequent development of a hexagonal superstructure. It appears from infrared spectrum examinations that a strong c-a bond strength anisotropy contributes to the higher Q's. 10% BaSn03 was added to the material to provide more sinterability. This raised the Q even more, even though the superlattice lines tended to disappear. Q values of 20,000 with K's of 24 were seen at 10 gHz.

Murata is pioneering the application of infrared spectrum analysis to the improvement of electrical properties of electronic ceramics. For details see the Journal of the American Ceramic Society (1, 1986) and the Japanese Journal of Applied Physics (6, 1986).

- 2) Murano from Sony discussed the addition of <2% Co to PbZrO3 to improve its properties as a dielectric resonator. Conventional solid state reaction techniques were used. After some materials optimization and after using a disc of SrTiO3-NiO-Nb2O5 in series with it, a relatively high microwave K (170) device with a Q of 1200 was obtained.
- 3) Sato from Oki worked on a complex rare earth, barium poly titanate composition that gave a slightly higher Q (1800) with about half the dielectric constant than the material shown by Murano. He claimed etchability as an advantage for electrode plating.

G. Anisotropic Materials

In addition to what is shown here, there is also an effort on anisotropic materials in Dr. Yamagida's lab (see below).

- 1) Kemora and Yamaguchi from Keio University used molten salt synthesis to make rod-like potassium-strontium niobate crystallites. The spontaneous polarization in these is parallel to the major axis of the rods and after extrusion these rods were quite well aligned. X-ray diffraction of sintered compacts shows consequently a very high degree of anisotropy. Similar techniques had been applied to barium titanate and gave there a 40% improvement in maximum d33.
- 2) Nagata (National Def. Acad.) prepared an oriented Pb5Ge3O11 type ceramic by adding silica to the base composition. During hot pressing first a glass is formed; this then recrystallizes with the C axis normal to the pressing direction. A highly anisotropic ceramic results with a maximum pyroelectric coefficient of 15 x 10^{-2} μ C/cm C, about 3 times that found in calcium stabilized PbTiO3. A g33 response as high as in PZT was mentioned.

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H. Relaxors and Piezoelectric Materials

Here dielectric constant as well as anisotropy of the coupling factors is a desired parameter, similar to what is being investigated in the U.S. (i.e. at Penn State). In addition, previous Japanese work tends to indicate that perovskite lead zinc niobate could exhibit rather high piezoelectric activity.

1) Harmer reported on transmission electron microscopy of lead scandium tantalate and lead magnesium niobates samples. Superlattice reflections, indicating short range order of magnesium and niobium ions over small regions, were found, even in what were thought to be disordered materials. The 'electrostatic charge imbalance was said to keep the ordered domains from growing.

- 2) W. Schulze analyzed lead magnesium niobate with excess magnesia and found a high dielectric constant, even though the excess magnesia seems to be concentrated near the grain boundaries. An effect of the magnesia on the ordering of the PMN structure is suspected.
- 3) Inagaki from Marcon Electronics Corp. showed barium and titanium to stabilize the perovskite structure in lead zinc niobate. Barium stabilization has been published previously by Penn State workers.
- 4) Ichinose (Waseda University) added as much as 35 mole% calcium (as well as Ba and Sr) to PbTiO3 and found a peak in the spontaneous polarization of 42 μ C/cm with a Kt of 55% and a curie point downshift of 400°C. The maximum KE/KD ratio was at 25% calcium. Nice work.

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- 5) Sakata (Science Univ. of Tokyo) investigated lead zirconate-lead tin zinc niobates and obtained relatively dense samples, having dielectric constants below 400 and a significate anisotropy of the coupling factors. Their d₃₃ values were near 42, d₃₁ values about 8.5 and d₁₅ values were near 150. The material seems to be an improvement over lead titanate for high frequency pulse applications.
- 6) Honda (Mitsubishi) inhibited the grain growth and increased the sinterability of sodium lithium niobate through the addition of 1/2% alumina. Dielectric constants of 110 and coupling coefficients of 42% seem to make also this material useful for high frequency pulse applications.
- 7) Tashiro (Nat. Def. Acad.) investigated piezoelectric and mechanical properties of lead bismuth sodium iron niobate-lead titanate solid solutions as a function of lead titanate content. The material has a significant anisotropy of its electromechanical coupling factor. The behavior is very similar as that of lead titanate ceramic sintered through doping with calcium, samarium or lanthanum. The author finds a close correlation between K_D and

the Poisson's Ratio. The problem of trying to relate a ratio to a constant is acknowledged. The author was probably not aware of previous work in relating the Poisson's Ratio to the Kp/Kc ratio.

I. Piezoelectric Transducers

Only little U.S. research on bending elements has been reported recently. Japanese work on this is reported in the following 3 papers:

1) Uchino from Sophia University presented the construction of a monomorph that used barium titanate reduced to a resistivity of about 10 8 OHM-cm. When coated with a surface barrier electrode, it showed as much as 100 $_{\rm L}$ m deflection with an applied field and it exhibited mechanical resonances that make it also useful for buzzer and pump applications. This was one of the more ingeneous devices shown at this meeting.

- 2) Saki (Toyo Soda) also showed a Barium Titanate based monomorph. It was initially reduced to semiconductivity and was then partially reoxidized-in from the surface, in so as to get a conductivity gradient and thereby (with voltage) a bending moment. The processing used is very similar to that applied to a high voltage fine grain barium titanate, surface-barrier type capacitor.
- 3) Tamura at Sony Central Labs showed me a piezoelectric bimorph that utilized a rather complex lead bismuth nickel zinc niobium titanium zirconiate as the driving material. A "shim plate" between the two piezoelectric driving plates was made out of oriented carbon fibers. This carbon fiber plate has more than an order of magnitude anisotropy in its modulus. This removes the mounting constraint from the driver plate to become narrower as its length increases (because of its Poisson ratio). As a result of this, a 35% to 50% increase in bimorph deflection was claimed. This appears to be a well thought-out remedy to a not always recognized limitation of bimorph operation.

- 4) Kikuchi, an engineer at TDK, evaluated the acoustic response of honeycomb-shaped PZT material. He found the radial resonance reduced by a factor of 8 in magnitude. Harmonics of these are almost completely absent and the thickness resonance was reduced in frequency by almost 30%. There is furtherore no indication of thickness harmonics. Stiffness and Q are also less than in solid disks. The application of horeycomb-shaped PZT devices as effective underwater acoustic sources is under consideration.
- 5) M. Kahn (the author of this report) discussed preparation and performance parameters of PZT 5A with photolythographically defined ordered void structures. A hydrostatic sensing gain of 199 db \pm 3.5 db up to 250 KHz was shown. The factors leading to enhanced tensile fracture strengths and fracture energies of these were also discussed.
- 6) Takeuchi (Hitachi) evaluated the response of 1-3 PZT/polymer composites as a function of the PZT pillar size and volume fraction. Coupling factors (K_p) as high as 0.38 appear to make this configuration useful in the planar vibrational mode as well as in the flexure mode. The latter could find use in a lower acoustic impedance piezoelectric speaker.
- 7) R.E. Ault discussed design parameters for composite transducers that can lead to the suppression of lateral resonnances. This is done by utilizing a super-lattice period in the composite that gives rise to wide, lateral frequency stop bands.
- 8) Jomura from Hitachi Metals discussed mechanisms for increasing the available strains in a ceramic, as for instance by volume changes caused by phase transitions. Transverse strains as high as 0.1% at 10 kv/cm were mentioned.

9) Abe from Toshiba discussed a polynomal expansion of the electric field in terms of the polarization, applied to determine the temperature coefficient of the electrostriction for a "modified lead zinc niobate ceramic".

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J. Piezoelectric Applications

- 1) H. Kamata at Oki showed me an assembly line where they are making about 20,000 Sonoboys a year. A substantial fraction of the assembly is done by hand, even though they have some automated materials handling equipment. They use monomorphs as omnidirectional sensors. These consist of a thin ceramic disc mounted on a brass shim in an aluminum or plastic cup. This was used in addition to other, more conventional configurations. The specifications of 10 different types of sonoboys that they have made are attached. HQS 6B is presently the most popular type (70% of their output). The sonoboys I saw in assembly used a seawater actuated battery that was able to power the buoy for up to 8 hours (shorter times were programmable). The construction of the bimorph sensing element as well as of the sonoboy itself did not appear to be hardened for elevated pressures or for shock loads.
- 2) R. Ting reported on a 6 foot by 6 foot hydrophone array which was made up of 5 inch square elements of PVDF encapsulated in flexible polyurethane. The difficulty with this material is in its loss of piezoelectric sensitivity at 60° C, its low dielectric constant and in its planar anisotropy. He also mentioned VDF -TRFE copolymers that are relatively stable up to 35° C. He also discussed the performance of a 1-3 composite made by Plessy that was said to have a g_h as high as 40 m/m/N with changes of only 3 db under static pressures to 35 MPa.
- 3) Two papers on piezoelectric ceramic actuators, one by Takahashi and another one by Yoshura (both from the NEC) described the advantages of a piezoelectric tape puncher in which small size actuators are mounted in close proximity: it

is relatively silent and with the inductive source described by Takahashi requires only little energy for operation.

4) Chubachi (Tohoku Univ.) continues to develop his line focus beam acoustic microscope. It tests local variations in elastic properties of a surface at 225 mHz. Significant differences in propagation velocity were shown across a PZT ceramic wafer. This is a sophisticated system that appears essential to make high quality surface acoustic wave devices.

K. Varistors

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- 1) Matsuyama (Tayo Yuden) discussed electrical properties of strontium calcium titanate based varistors, indicating that lower oxygen pressure results in lower bulk resistivities. After indiffusion of sodium oxide this gives varistors with higher alpha at larger currents and therefore a larger surge energy absorbing capability.
- 2) TDK are also making varistors, both out of reduced and grain boundary oxidized strontium titanate as well as out of TiO_2 . It appears that the TiO_2 based varistors have about twice the dissipation factor of strontium titanate based devices below 2 KHz, but at higher frequencies their loss is significantly less.
- 3) An interesting varistor application is a washer like structure made by TDK with segmented electrodes. It is designed to be mounted behind and connected to the collector of fractional horsepower universal motors to suppress arcing and prolong brush-life. Only a very reliability conscious user of small motors could be expected to pay the required premium for such a feature.
- L. Substrates and Mechanical Properties
- 1) Takahashi from Toshiba showed data on the use of yittrium oxide as a sintering aid in aluminum nitrate. Its quantity has to be closely controlled

but it is claimed if that the oxygen content kept below 1%, 2 to 3 times the thermal conductivity of aluminum nitrate that is hot pressed without a sintering aid can be achieved.

- 2) Nihara (Nat. Def. Akad) discussed strength and fracture toughness of CVD prepared silicon carbide. There was no glassy phase in the grain boundaries and as a result the material had good high temperature strength. The CVD process conditions were manipulated to generate multiple stacking faults and these faults were found to deflect cracks and increase fracture toughness considerably. Very significant work.
- .3) Yamamoto (Nat. Def. Acad.) determined stress magnitudes and anisotropies in various poled lead titanate and PZT compositions by measuring indentations crack lengths.

M. Photovoltaics

- 1) Uchino (Sophia Univ.) described a relay that was activated by the photostrictive effect in PLZT: light generates charges at the surface of a bimorph. The charge accumulation causes a photovoltage and the high d33 of the poled PLZT then causes strain and a deflection of the PLZT. This was used to operate a snap switch. Illumination of an oppositely poled PLZT strip causes an opposite voltage that can be used to reverse the switch action. The high device impedance causes it to require 2 sec to 100 sec for equilibriation. The behavior is described graphically. A nice piece of device engineering.
- 2) B. Koepke reported on a study of PLZT compositions designed to obtain optimum light switching. He found the lowest switching levels with Zr/τ_1 ratios of < 65/35 and with <9.4% La.
- 3) A. Haertlig reported on photoconductivity in biased PLZT; When a voltage is used to close a PLZT shutter to (block) strong light, polarization at the

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HGHT LICHT	ON .	NO	NO NO	NO	NO	NO	ЖO	YES	ИО	ON
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UMBER OF	31	31	31	31	31	3.1	31	12	3.	31
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electrodes causes then an internal bias, that changes the resultant shutter characteristics.

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N. Modeling

- 1) Banno (NEK) elaborated on his previously introduced cubes model for voids in ceramics. He introduced a shape factor to describe voids that are isotropic only in the X-Y direction and calculates electrical, mechanical and piezoelectric properties for ceramics having porosities up to 15%. Interesting correlations to experimental data are shown for conventionally pressed materials, assuming nearly round pores and for hot pressed materials assuming an X-Y diameter twice times the Z thickness. This model could be applicable to the determination of average pore shape.
- 2) Kagegava (Chiba Univ.) showed a technique for determining compositional fluctuations from the width of x-ray diffraction lines. The calculation is based on the differences in line width obtained from different lattice spacings. Very elaborate and very interesting.

III. Panel Meeting on Piezoelectrics

Professor Newnham did an outstanding job at initiating and encouraging discussion. It would be my recommendation though to try to schedule the panel in the future for the second or third day, so as to give the participants a chance to become better acquainted first.

- 1. There were some comments about making geometries with graded impedances, as one could get from filler concentration gradients in 0-3 composites.
- 2. PVDF material apparently has been a disappointment. Some of the shortcomings quoted concern its high output impedance, its large transverse response and its excessive flexibility that were quoted to give rise to noise.

- 3. There was some discussion about the d₃₁ parameter to have imaginary as well as a real components: Positive d₃₁ values were measured in lead titanate at certain temperatures. There was also some discussion on the contribution of the electronic structure to the high polarization and Curie point of this material. Its anisotropy is particularly useful in high frequency piezoelectric 1-3 arrays where the interaction between the individual elements in the transverse mode has to be minimized.
- 4. There was some discussion of the mechanisms that control the d_{31} parameter. One is the Poisson ratio of the material and another one is, caused by a high c/a ratio that can give rise to microcracks or microfissures that reduce the d_{31}/d_{33} ratio. Excessive poling voltages can do the same.
- 5. NEC was specifically quoted as having a strong position in the manufacture of low cost piezoelectric motors.

Hard piezoelectric materials with low hysteresis, low aging and high mechanical toughness are generally preferable for this application. In addition, a high Q increases the potential efficiency of the motor. This is critical in battery powdered applications. In addition one of course wants the highest possible strains. Ceramic compositions near phase boundaries look therefore most attractive, except that materials with strains in excess of 6% (i.e. Bismuth Ferrite) are self destructing. Another approach is the utilization of electrostrictive phenomena and consideration is being given to strain magnification through the preparation of non-homogeneous devices.

6) Apparently there is a direct inverse relationship of the coupling factor (KT/Kp) ratio to the ionic size of dopants in lead titanate. Doping with gadolinium gives the highest and with lanthanum gives the lowest anisotropy. Cobalt doping is an exception, it gives a relatively high anisotropy for its ionic size.

IV. Visit to Dr. Yamagida's Laboratory at the University of Tokyo

Dr. Yamagida and his coworkers are involved in a variety of activities: 1) They are trying to raise the anisotropy of barium titanate made from fibrous precursors (Journal of the American Ceramics Society, April, 1985) by doctor blading, stacking and firing thick films. 2) One of Dr. Yamagida's main interests is the development of materials for sensing applications. The attached table summarizes some of his efforts in this area. Their work on porous zinc oxide is continuing with various electronic dopants so as to increase its sensitivity and specifity. 3) They have investigated the PTCR effect and lattice parameters in barium titanate doped with neodymium. They have verified self-compensation (occupancy both of barium and titanium sites) at neodymium concentrations above .15%. (Journal Korean Ceramics Society, 1985). 4) They have looked at additions of .5% to 10% of alumina to ZnO, to zirconia and to strontium cloride to increase the conductivities of these systems. The responsible mechanisms range from lattice substitutions in ZnO to interfacial ionic conductivity of alumina particles in strontium cloride, as well as in calcium fluoride and in barium fluoride. 5) They have a program evaluating conductivity and weight loss behavior of single oxide systems (rock salt structures) as NiO, MgO, and MnO and others that are amenable to modelling.

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SENSOR CONFIGURATIONS

References(1)	Chem. Soc. of Japan 4/86	J. Mat. Sci. 5/86	J. Am. Cer. Soc. 1/85	Chem. Soc. Jap. 6/85	J. Am. Cer. Soc. 7/86
Sensitivity	1.5 x current decade of PCO ₂	40 mV decade of PCO ₂	25% Res. change with 400 ppm C3Hg	4 x wet/dry voltage	100 x wet/dry current
Operating Temperature	260°C	20009	400°C	25°C	25°C
Configuration	Mechanically contacting surfaces	one electrode coated with LiCO3	. Porous body Pt impregnated	Sintered body ZnO exsolved around NiO grain cores(2)	Mechanically contacting surfaces
Sensor	CuO-ZnO	Beta A1203 bulk	Zn0	(Zn _{0.8} Ni.22)0	ZnO-(Ni0.97 Li0.03)0
Sensitivity to	00	² 00	Reducing gases	Relative humidity	Relative humidity

(1) All co-authored by H. Yamagida (2) 800° C for 336 hrs.

6) Kishimoto from this laboratory presented at the Toyama meeting an excellent piece of work on pure BaTiO3 tapes, that had been mechanically compressed after burnout. He showed that after firing he obtained a relatively flaw free material, in which both electrical breakdown and mechanical bending test failures originated in the grain boundaries. This work had been preceded by high temperature breakdown studies in MgO. There they found localized thermal breakdown channels (similar to what we are seeing in PTCR devices) and also lower breakdown strengths in single crystals in the presence of dislocations. They found even lower breakdown strengths in polycrystalline structures (Journal of Material Science, 1985).

Professor Yamagida's group contains 30 people. They have constructed some relatively sophisticated systems for heat treating and testing of devices under complex conditions of gas composition and gas flow. They also have set up a rudimentary tape casting facility. They seem to be quite strong on equipment they put together themselves.

V. Plant Visits

1) At the central laboratory of the Sony Corporation, they showed feasibility of increasing the memory capacity of a laser disk memory by three orders of magnitude. This requires cooling the storage media to the temperature of liquid helium and frequency modulating the laser beam, allowing a read out at each spot at 1000 different frequencies. This is made possible by the different environments of neighboring atoms into which die molecules in the storage media are frozen: The exact frequency response of each die molecule is determined by the force field generated by surrounding molecules.

They also had an impressive array of CVD reactors, designed to control the gas flow so as to permit abrupt changes in the compositions of the deposited films. More informally we discussed technical information transfer:

They were not complimentary at all on the scope and quality of technical Information from Russia or China. Information generated in the United States was quoted as being very useful but information generated in Japan was said to have even more engineering content and show more applied results than that generated in the United States.

2) At the TDK capacitor plants in Akita, Mr. Furukawa explained that they are mixing their raw materials in high speed, plastic coated, continuous flow, disk mills, with the material recirculated two or three times until the right particle size is measured (on a Leeds and Northrop microtrack). The material is then filtered and calcined in Saggers. At least for disk capacitor preparation the material is then spray dried.

They make 560 million disks a month. Thinner disks are made by punching sheets, heavier parts by rotary pressing. On the surface their in-line lead forming and disk assembly machines look very similar to equipment used more than 20 years ago in the now almost defunct U.S. disk capacitor industry.

Some changes included a novel soldering approach where-in only the leads were dipped into the solder pot and the solder ball that accumulated on each lead end was used to provide solder when sweating the leads to the disks. Two cleaning and coating stations were also included with each assembly machine. An automatic outline inspection machine using video cameras, was also used. The only significant amount of manpower in the whole line was at final packaging where the capacitors strips were responled from the large wheels used in the line to small packaging wheels. At that location a girl inserted capacitors by hand into the empty spots on the belt where previously rejects had been pulled out by the test machines.

One reason for their success in building and maintaining their disk manufacturing operation is probably in their local customer base. Disk capacitors are largely used in the assembly of entertainment equipment, of which there is practically none left in the U.S. It appears though that history has come a full circle, insofar as part of the Japanese disk manufacturing operations are being transferred elsewhere. Not only due to lower labor costs, but also because the market for disk capacitors that has developed in other countries.

TDK are using 3 different methods for making multilayer capacitors: I was shown their most mature activity in which the dielectric as well as the electrode layers are laid down by screening. The latter operation plus the drying ovens as well as a return belt and the required substrate handling fixtures were all in one integral unit, better than 15 feet long. Because drying is required after each screening cycle, the output of each machine is relatively low. I saw 32 of these machines. They use one operator for each 4 machines. The operators (who are fully gowned for dust reduction) seemed to spend most of their time in cleaning screens from old set-ups and setting up for new configurations. As in most capacitor manufacturing there is a significant number of different parts that have to be made. The equipment looked very clean, seemed to be running very smoothly with lots of chrome plated and clean, painted surfaces in evidence. As in all manufacturing operations that I visited, everybody removed their shoes at the main entrance.

They used diamond wheels for dicing the green pads. This is slower but makes cleaner cuts than the blade dicing technique commonly used in the U.S. Automation of the dicing machines for X and Y cutting on the same machine was still being set up. There was no smell from their binder solvent recovery

operation nor from their burn-out ovens. They use 2 day air burn-out in ovens, similarly to what is practiced in the U.S.

Multilayer capacitor firing is done on zirconia slabs onto which the chips are loaded in a dense, single layer from an automatic loader. For termination of chips, I saw them using 4 U.S. made Palomar terminators. This was one of the few activities where there were a significant number of technicians attending an operation.

They had a room full of automatic chip sorting and testing machines. In another area there was a number of automated visual inspection machines, in which dual video cameras hooked up to a computor were utilized to automatically inspect the outline of chip solder coverage from each side. They use cartridges to feed the chips to and from the machine. Very low reject rates were observed in both operations.

TDK are also making a range of positive temperature coefficient products including a line of honeycombs. They are trying to introduce these in clothes dryers and mentioned also baseboard heater-type applications.

In the afternoon Mr. Furukawa and Mr. Yahagi discussed their development work on compositions and grain size control for internal barrier layer strontium titanate based dielectrics (via adjustments of stoichiometry) and also by additions of maganese oxide and of 10% calcium titanate. In addition they seemed quite concerned about factors leading to delamination in multilayer capacitor: They are using exclusively 100% palladium electrodes with high fired dielectric compositons. There seems to be an incipient development of silver bearing internal capacitor electrode systems. They showed TGA curves and suggested that the rapid weight loss at the temperature that the palladium oxide becomes unstable may be responsible for their delamination problems. They had evolved a thermal shock testing technique

which was said to be able to detect delaminated capacitors. They seem to be well aware of U.S. publications in this area. TDK seem to be relatively strong in equipment design, their engineering manager seems to be an expert in this area. They claimed to be able to sell chips at 2 yen each and make a profit. Their equipment was constructed like money was no object, with extended unattended operation to be one of the foremost design parameters. As noted, low output rates were compensated for by more machines.

In a different location (near Tokyo) TDK has a substantial operation manufacturing hybird circuits. They were said to use 1 1/2 ton of silver paints a month and an unspecified amount of Birox resistor material from Dupont. Low frequency as well as microwave hybirds are made there in an automated assembly line. It was said to have 30 automatic screeners with parts handled in cartridges, permitting automatic loading and feeding into processing equipment and kilns. The majority of these hybirds was said to go into telecommunications applications.

3) Dr. Banno gave me a tour through the NGK Spark Plug plant. This facility is heavily automated: They have a substantial metal working plant in which relatively old German and American-made equipment is automatically making the metal parts for spark plugs. The material here is handled in bulk with manned fork lifts moving large containers full of small parts. In the plating operation and in the ceramic preparation and assembly plant, 90% or more of materials handling is automated.

Their alumina is wet milled and spray dried. The spark plugs are hydrostatically pressed, go through a curing cycle, are cut and ground to shape, fired, marked, glazed and fired again with very little human intervention in the process. Copper electrodes are used in the spark plugs,

and nickel plating is applied to the business end of the electrode to provide erosion protection. Talcum is used for sealing the electrode to the insulator. A significantly larger fraction of the machinery on the floor is dedicated to handling, moving and aligning the parts than to the operations themselves. It appears that careful design, construction and upkeep of such equipment is at least in part responsible for the Japanese productivity. I saw relatively old equipment running unattended, having a multitude of interlocks and safety switches monitoring its operation. Apparently mechanical linkages and relay logic were broadly used to program the equipment.

NTK (an affiliate) is marketing a wide range of "fine" ceramic products. They have a broad line of 455 KHz piezoelectric band pass filters and fm discriminators, 7-15 MHz frequency-control resonators and piezoelectric ceramic-metal, as well as ceramic-ceramic bymorph elements for audio tone generators. They also have an extensive line of piezoelectric ignitors. They also make a variety of piezoelectric transducers: Some are finished into hydrophones, others are assembled into transmitters in what appear to be both military as well as civilian applications. They are also making piezoelectric oil level detectors, engine knock sensors as well as both TiO2 and zirconia oxygen-pressure measuring elements. They furthermore have an extensive line of alumina insulators, heater supports, thread guides, metallized substrates for microcircuit packages as well as silicon carbide cutting tools, bearing elements, compressor rotors plus a variety of ceramic parts for air-cooled internal combustion engines. They also showed me beta alumina, solid electrolyte batteries presumably designed for load leveling applications in electric power grids. Altogether a very respectable product line.

VI. Summary

A U.S. manufacturer would find it nearly impossible to make at a profit from a broad line of new devices with special materials, as I saw at NGK, without a more extensive and costly incubation time than is usually found acceptable. One has therefore to conclude that the Japanese implementation of some of these technologies is due to their use of other than early profitability criteria when they make decisions on the introduction of new products. The wide spread of their decision making process may contribute to this: a midlevel manager who (at least in Japan) is looking at a 15 year future with his employer, is more apt to take the long view than a senior executive who is concerned with the reaction of stockholders, most of whom may have only little longterm commitment to their corporation.

Notwithstanding a low unemployment rate, (by U.S. standards) there appears to be quite a sense of competition in Japan. It is not certain that people in Japanese industry work any harder than in the U.S., but Japanese professionals seem to be putting in longer hours. One cannot fail to be impressed by their factories. It appears that they have set out to do things the "right way" with a willingness to spend rather substantial amount of money to obtain properly designed manufacturing equipment. It appears that because of a conceived high labor cost (that still may well be lower than in the U.S.) the Japanese have improved their productivity by beating on banks and on machine designers in preference to beating on their production force:

They have automated many hard to mechanize materials-handling operations that manufacturers in the U.S. often find it more profitable to perform with manual labor. One is led to the conclusion that funds expended on equipment designers and model builders somehow carry much lower overhead adders than those expended for direct labor.

I saw numerous Japanese items that are sold in the United States at lower prices than in Japan. This would imply that at least in 1986 Japanese manufacturers and traders exported merchandise at significantly lower profit margins than were extracted from sales within Japan.

X.

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The support of advanced technologies by the Japanese government takes many forms; for instance as suitable sensors are being developed, their use is mandated universally, as for instance sensors for the presence of escaping cooking gas. Right now there seems to be some discussion on mandating the use of ceramic PTCR heaters instead of nichrome in laundry dryers and even in space heaters. The lower surface temperatures of PTCR heaters reduce the fire hazard posed by dried lint, paper scraps, etc. These applications have been considered in the United States more than 10 years ago but were rejected then, largely due to the high material costs. There are a number of Japanese manufacturers who have now built up a significant PTCR manufacturing capability and if the use of ceramic PTCR heaters is legislated, one could expect roughly a doubling in the tonnage of electronic ceramics produced in Japan (PTCR devices have a much larger mass than multilayer or even disk capacitors).

When looking at the scope of Japanese research, the breadth of their product lines (specifically in high tech ceramics) and at their investment in automation and materials handling, one is forced to conclude that many decisions on expenditures and investments are made with only small regard to the immediate return on the investment. One can easily infer that centralized funds are made available for the sole purpose of advancing technology and raising productivity. The government then has a vested interest in supporting the market for new products, i.e. by legislation or by policies that lead to increased exports. With the recent downturn in Japanese exports one can

expect increased encouragement of internal Japanese consumption. The decision to initiate for instance direct satellite broadcasting in Japan, has given rise to a considerable amount of activity towards the development and manufacture of microwave home satellite receivers: 10 gHz frequencies allow receiving dishes only a little above 2 feet in diameter and stable small resonators are needed for local osscillator frequency control. They are presently transmitting on two channels, giving excellent pictures. The use of even higher frequencies is envisioned. As noted, a significant amount of research in ceramic dielectrics is directly attributable to this decision.

Japan is still a land of contrasts. One sees people using abacuses, but in many areas one notices penetration of advanced technology in consumer areas which are more advanced than those found in the U.S: One sees for instance hand calculators with graphics programs and displays, pay television in the back seat of taxi cabs, computorized wake-up calls in hotels and other sophisticated consumer electronics. The quality of their train system has no equal in the U.S.

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REPORT ON U.S.-JAPAN SEMINAR
ON DIELECTRIC AND PIEZOELECTRIC CERAMICS

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My trip to Japan was very brief because of teaching commitments at Penn State. I spent just one week in Japan with air flights on two consecutive weekends. On Sunday, November 9 through Wednesday, November 12 I attended the Seminar at Toyoma, after which I visited N.E.C. on Thursday and spoke at the Satellite Symposium Friday.

I was favorably impressed with the quality of the Seminar on Dielectric and Piezoelectric Ceramics. The setting at Toyoma was conducive to extensive interaction between the U.S. and Japanese delegations. The auditorium at YKK was excellent and the meeting organizers (Prof. Yamaguchi and Dr. Freiman) did a fine job in selecting participants and laying out the program.

My only regret is that there were not enough U.S. industrial participants. About 80% of the U.S. delegation was from university and government laboratories, while 80% of the Japanese were from industry. This is not meant as a criticism of the selection process. I know that Dr. Freiman and Dr. Pohanka tried very hard to recruit more industrial scientists for the meeting. A change in policy involving guidelines for the meeting needs to be invoked before the next symposium. Both delegations should be more evenly balanced between industry, university, and governmental scientists.

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In regard to the technical content of the meeting, it is difficult to comment on all the papers presented but I discuss a few highlights from the Japanese poster sessions in the following paragraphs.

CAPACITORS

Since the last U.S.-Japan symposium, several Japanese capaction manufacturers have commenced production of MLC with base-metal electrodes. The papers by Kishi (Taiyo Yuden), Sakabe (Murata) and Fujikawa (Kyocera) described BaTiO3-based dielectrics modified by Sr, Ca and Zr. The presence of excess calcium in the titanium site seems to be critical in preserving high resistivity during firing cycles under low oxygen pressure. Capacitors meeting X7R and Y5V specifications are in production. One wonders whether or not copper electrodes will be used next.

MICROWAVE RESONATORS

Several papers describing microwave dielectric resonators were presented at the Toyama meeting. Pb(Zr,Ce)O3 ceramics developed by a team of scientists from Sony and Narumi China has an unusually high value of dielectric constant (K~170) and electrical Q (~1200) at 3 GHz. The K value is about eight times larger than other resonator ceramics, allowing significant reduction in resonator dimensions. The use of antiferroelectric ceramics was anticipated by others but this is the first production lot.

The temperature coefficient is not quite as small as some dielectric resonators, nor is its Q as large at the $Ba(Mg,Ta)O_3$ - $BaSnO_3$ ceramics reported by Murata. The dielectric constant of

this material is only 24.5 but the Q at 10 GHz is 20,000, a new record!

TRANSDUCERS AND ACTUATORS

Laser-induced chemically etching of PZT was demonstrated by Shiosaki and Kawabata of Kyoto University. This appears to be an extension of Susan Trolier's work at Penn State on etched tape-cast transducers. Shiosaki showed a lot of interest in the paper she gave at the ISAF meeting in Lehigh, although he did not credit her work. By irradiating the ceramic in a cool etchant he greatly increased the rate of etching, which is a useful way of "customizing" the transducer design.

The two papers given by Uchino's group were excellent. The photodriven relay using PLZT ceramics produces deflections of more than 100 μm . A monomorph actuator using a ferroelectric semiconductor layer was also described. When a voltage is applied, the field builds up on the piezoelectric layer causing a sizable deflection of the bilayer device.

The green-sheet punch made by NEC was also impressive. More than 1600 holes per minute were punched by the piezo-electric actuator.

COMPOSITE PIEZOELECTRICS

Takeuchi (Hitachi Central Research Laboratory) described some experiments on planar mode vibrations of 1-3 diced PZT-

epoxy composites. Surprisingly large coupling factors of 35% were observed for samples containing 20 to 60 volume % PZT. The materials look to be useful for piezoelectric speakers and other flexure mode devices.

The paper by Varaprasad (Naval Dockyard, Bombay) was interesting. He has been experimenting with various polymer matrices for 0-3 composites. There were some unexpected changes in the polymer dielectric spectrum with and without PZT filler. It is not clear why the spectrum changes. Dr. Gillman gave an interesting poster on the composite hydrophones made by Plessey Australia. The sensitivity surpasses any other commercial hydrophone material.

NEC VISIT

On Thursday, November 13 I visited the Central Research Laboratories of Nippon Electric Research with Dr. Pohanka, Prof. Schulze, Dr. Haertling and Prof. Burton. The visit was disappointing in the sense that we were not shown the research laboratory or the pilot plant operation for integrated ceramics. Instead, we received a cordial welcome and taken to the showroom for electronic products.

After lunch there were talks by NEC scientists and the U.S. visitors. The NEC staff gave good reviews of recent progress on AlN substrates for high power transducers. Remarkable thermal conductivities are achieved with fully-dense aluminum nitride ceramics.

Dr. Utsumi went over the work on monolithic multicomponent ceramics (MMC). Considerable progess has been made since I last visited the lab in December 1985. At that time they had just announced the interstratified packages containing high-and low-permittivity tapes with screen-printed circuitry and ruthenium oxide resistors, a four-phase co-fired system.

Four new advances were reported during our visit: display panels, ink jet printers, UV currable dielectrics, and controlled space processing. Luminescent display panels make use of the high K layers in an MMC package. By placing a high permittivity layer just below the electroluminescent phosphor, considerable field enhacement and brightness is achieved. The phosphor display layer on the outer surface makes good use of the area cleared by burying capacitors and resistors inside the package.

Ink jet printers can also be added to the package. The miniature multilayer printers described at the Toyama meeting appear to be compatible with MMC technology. Symmetric electrode configurations were found to be superior to the one-sided arrangement reported earlier. With printes and display the MMC technology will find many additional applications.

Integrated ink jets make use of controlled space technology. This is a way of incorporating patterned channels and cavities inside ceramic bodies by utilizing shaped pieces of fugitive phase. The processing is similar to the porous PZT composites made at Penn State and NRL but extensive use is made of photolithography. This makes it possible to generate

intricate porosity patterns inside the ceramic without timeconsuming processing steps.

The fourth advance is a UV-curable dielectric paste made from lead borosilicate glass and alumina powders embedded in an organic photopolymer matrix. Using patterned masks, it is possible to build complex 3-D circuitry with via holes as small as 40 microns.

MMC technology is advancing very fast at NEC.

My last day in Tokyo was spent at two meetings. At the request of Prof. Yamaguchi and Dr. Freiman, organizers of the Toyama meeting, Prof. Vest, Dr. Pohanka, Prof. Harmer and I spoke at a satellite meeting in Tokyo. The same day I took part in a second meeting with Japanese industrial and govenment leaders. The second meeting was organized by Dr. Shirasaki of the National Institute for Research on Inorganic Materials. There were no Japanese presentations at either meeting.

A Review of the 3rd U.S.:Japan Seminar on Dielectric and Piezoelectric Ceramics

Prepared by

Walter A. Schulze

of

Alfred University

The following is a series of observations and highlights on the poster session and plant visitations resulting from this interaction. There is no attempt made to analyze the "big picture" concerning long range US or Japanese superiority in this market area except to reinforce the conclusion from the meeting four years ago. The Japanese companies appear to be committing a considerably larger fraction of their gross revenues into research and development than their US counterparts. It appears that the emphasis is still on development and that products are stressed considerably above understanding. My personal projection is that the Japanese industrial research and development is progressing more rapidly and is definitely ahead of their US counterparts. This is visually intensified by the willingness of Japanese companies to let their personnel publish.

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The visitation to facilities represented a considerable change from four years ago. I understand that there were still some exceptions, but the visitations to NEC and Hitachi offered no observations of production, and in the case of NEC, not even viewing research facilities was permitted. This may be a response to the very limited number of tours offered to Japanese participants after the second US:Japan Seminar.

The principal question that must be addressed is if this seminar series is worth the expense? My feeling is that the answer is yes, if the goal is to expose a broader group of US workers to the progress of the Japanese than would normally exist and also foster knowledge of and interaction with the key Japanese workers in piezoelectric and dielectric ceramics. The interactions every two years serve a number of educational and social functions. They allow a broader view of the Japanese technology than most of us could afford to accumulate. This was most dramatic in the first seminar when the unanimous conclusion was that we were even further behind than we thought. The other educational benefits are the obvious lead time derived from presentations well before publication and the somewhat unpredictable flow of information during personal conversations. The social interactions between individual researchers allow the development of an understanding of why some of the work is conducted and how the results are derived. These processes are roughly construed as "reading between the lines", and in some cases, can add considerably to technical results. Other bits of technical information continue to flow throughout the years in the form of notes, Christmas cards, technical preprints, and exchange of

samples.

The above benefits are real and functioning for the University participants but are tragically lacking for most of our industrial friends since they chose not to participate. This may be attributed to their inability to fully participate in presentations and plant visitations due to corporate policy. This is also attributed to a few oversights as evident by the omission of Transelco. I personally feel saddened by the lack of US industrial participation but can offer neither reasons or solutions. If the Japanese industries withdraw in the same percentage, the series will become useless. An alternative to a formal series would be to make equivalent funds available to send small groups to selected Japanese conferences and trade shows with the purpose of gathering information, visiting facilities and developing personal contacts.

The following are comments and additional information on the posters presented at the seminar listed by day and number as given in the abstracts.

M-1

It is very nice that this paper is of US origin since it is one of the first demonstrations of electrically usable sol-gel derived ferroelectric film. The ferroelectric properties are comparable to bulk properties and the processing is compatible with Si substrates.

M-4

This paper represents the exploration of a different approach to the preparation reactive, high purity $BaTiO_3$. The hydrothermal derived powder showed good sintering at 1200C and developed predictable dielectric properties without sintering aids.

M-6

This work was unknown to me and represents a significant advancement in the preparation of complex shapes and composites. The technique opens up many possibilities for the preparation of devices at higher frequencies (higher than are currently possible). The fact that this has already been shown to be useful on ferrites suggests that it may also be significant in producing micro and millimeter wave devices.

M-15

This is an important statement because of the tendency of workers to consider MLCs as purely electrical devices. Thermomechanical relations should be considered in any complete analysis.

M-16

As usual, Martin Harmer's observations continue to add to the understanding and confusion (things are more complex than we perceive) of relaxor dielectrics. I found the statement that he has observed differences in ordering near the grain boundaries particularly interesting since we observe ordering changes as viewed by the dependence of the dielectric constant on temperature. It appears the material formed later by the expanding grain boundary may be more ordered.

M-22

Yamashita's work demonstrates the continued progress made by many Japanese researchers on relaxor dielectrics. Conversations with the author indicate that this system is very convenient in that it can be modified (as with BaTiO₃) to fit many of the normal temperature classifications from a single base system.

T-1

I found it very interesting to see a group pursuing antiferroelectrics as a high K, high frequency dielectric. The losses should be much lower since the domain walls should not couple with field. This is similar to work started at Penn State 3 to 4 years ago.

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All these microwave studies demonstrate the continued willingness of the Japanese to chase formulations on empirical grounds. The advances must be very expensive and show their resolve to dominate a specific market segment.

T-3

Dr. Wakino's group appears to be one of the few which has programs that utilize high frequency spectographic analysis to project dielectric response and to approach the problem of a low loss in a high frequency dielectric in a scientific fashion.

T-4

Dr. Nishigaki's high frequency dielectric material, like his low frequency material, is extremely complex but works. This, again, suggests an intense empirical study.

T-18

Photostriction in its present form represents a laboratory curiosity. These interesting and obscure phenomena should be remembered to be considered for the odd application. What they do indicate is that Dr. Uchino is a very intelligent and imaginative worker with good industrial contacts. He will surely be one of the major players in Japanese ferroelectric research for the following decades.

W-4

It was rewarding to see the pressure stable hydrostatic response from the lead titanate based ceramic. A good test of the usefulness of this seminar series would be to see if Bob Ting's appeal for new hydrophone samples elicits a good response from the Japanese participants.

W-12

This device may or may not be important in its own right, but again shows the range of Uchino's interests and his industrial contacts.

Roundtable on piezoelectrics

Tuesday evening I attended the roundtable on piezoelectric materials and devices. The attendance was sufficient to fill the room with a few late comers having to sit away from the "Japanese" table. The following is most of the list of topics chosen by poling the participants; no information was recorded as to how many votes were for each topic.

- 1. Why does modified lead titanate have a low transverse coupling and what are the latest models?
- What are the latest miniaturization techniques?

- 3. Is there any recent information on high displacement actuators?
- A request for more information on piezoelectric motors and their applications.

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- 5. What activates a high d coefficient in piezoelectrics?
- 6. How are d" and k" increased in porous material?
- 7. Are there any new composites with large hydrostatic response?
- 8. A request for discussion on the strong piezoelectric response of tunsten-bronze material.
- 9. A request for discussion of artificial symmetry.
- 10. What are the latest advances in thin film piezoelectrics?

My notes on the discussion are very broken, but the impression is still very clear that the roundtable was well attended, had good participation by both groups, and was definitely worthwhile. Probably more than half of the time was spent discussing the piezoelectric response of modified lead titanate. The discussion centered on trying to understand the recent Wersing model. As usual, there was a heated debate as to the role of microcracking in decoupling. The consensus still seems to be an admission that every piezoelectric ceramic has some microcracking, but it is not significant in modified lead titanate. There is still a strong interest in increasing the k of lead titanate.

Other observations are the following:

Americans do not generally understand piezoelectric motors, probably because we do not have the markets.

Laser enhanced etching may open new approaches to the fabrication of high frequency resonators.

There are now five manufacturers of 0-3 composite in Japan and it is

probably better than PVDF. Also, "someone" now has a 0-3 that works at 13 MHz. Ask Dr. Cross!

In conclusion, I felt that this roundtable was very helpful and would recommend this format for other meetings. One improvement would be the addition of a large writing area.

Company Visitations

I do not use the common term plant trips because I saw no manufacturing.

NEC

The NEC format was very disappointing, but we were treated very well. The principal interaction was 15 minute talks by both US and Japanese participants. All the technology discussed has, I believe, been previously presented before this meeting. I personally found three things very interesting.

There is a Canadian exchange student working at the NEC Central Lab. I believe he said he was from Dr. Sayers group.

The glass fluxed fully integrated interconnect substrates are impressive when you can actually handle them. When I asked about their availability, I was told that the technology was being transferred to production. I believe US schools and industry are just starting in this area (excluding IBM).

They have been working on combinations of antiferroelectric and relaxor ferroelectric materials for dielectric applications. The results look very similar to the PLZT work.

Hitachi Central Laboratory

The Hitachi tour was more interesting in that we were allowed to visit some research areas. I have only two observations that may be useful.

The high frequency 1-3 composites seem to be struggling for production level applications. The medical arrays do not seem to be significantly

superior to displace current technology, and applications such as speakers are only laboratory exercises. Also, the exhibit on 1-3 composites has been removed from the Hitachi Laboratory Exhibition Hall.

Hitachi has produced very good quality PbTiO₃ thin film epitaxed on SrTiO₃ single crystal The Pt electrode strips disturb the crystallinity. When I asked why the SrTiO₃ was not reduced in an electrode pattern by local diffusion of dopant, they wanted to drop the subject and then admitted they had applied for a patent in that area.

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TRIP REPORT

1986 JAPAN-U.S. STUDY SEMINAR ON DIELECTRIC AND PIEZOELECTRIC CERAMICS, AND RELATED LABORATORY VISITS, NOVEMBER 8-19, 1986

Donald M. Smyth Materials Research Center Building #32 Lehigh University Bethlehem, PA 18015

THE THIRD U.S.-JAPAN SEMINAR ON DIELECTRIC AND PIEZOELECTRIC CERAMICS, AND RELATED LABORATORY VISITS, NOVEMBER 8-19, 1986

I. INTRODUCTION

This third joint seminar gave another outstanding opportunity to exchange information and ideas with our Japanese colleagues. The professional relationships developed during these three meetings have given valuable insight into the Japanese technical operation and planning. As in the case of the earlier meeting in Japan in 1982, this meeting offered the added attraction of visits to various laboratories and production facilities.

The seminar was again characterized by a Japanese delegation that was mostly industrial and a U.S. group that was almost entirely academic. The very meager participation by U.S. industrial scientists was extremely disappointing. The presentations reflected this imbalance in that the U.S. posters tended to be more basic. As before, I found the Japanese scientists very much interested in the application of our more basic approach to their problems. I was particularly interested in the development of multilayer ceramic capacitors (MLCs) with base metal electrodes (BMEs). I first heard about the work at Murata at the 1982 seminar, and at least three Japanese companies are now manufacturing these devices in significant quantities. In the larger sizes these capacitors have the potential for replacing solid tantalum capacitors for some applications. I have emphasized the discussion of this area in this report.

I am also interested in the progress in Japan in applying the principles of defect chemistry. While the group at Murata does this quite successfully in their work on dielectric compositions for BMEs, the effort at the National Institute for Research in Inorganic Materials (NIRIM) has its problems. I could not agree with the interpretations offered for any of the three separate projects described to me.

The visits to laboratories and production facilities were notable for their openness and candor. For example, we were given a very

thorough tour of Murata's main production plant for multilayer capacitors. The work in progress in various laboratories was discussed in detail, and while it is unrealistic to expect to learn about their latest hot ideas, the discussions were reasonably up to date. Questions about future directions and plans were not obviously avoided. I thought that this attitude was quite remarkable, and quite a contrast to the response of U.S. industry on the other side of this exchange. Frankly, I feel that I now know more about the Japanese ceramic capacitor industry than I do about the U.S. counterpart.

The Seminar and the visits were very well organized. The meeting facilities made available by YKK were outstanding. The cochairmen, Dr. Freiman and Professor Yamaguchi deserve congratulations for a very well-run meeting, and the Office of Naval research and Dr. Pohanka should be commended for their foresight in making these joint meetings possible.

The report is divided into two major parts: a section on the seminar presentations of particular interest to me, and the discussions concerning them; and a section describing visits to laboratories at Murata, NEC, NIRIM, and Sumitomo, and to the Murata multilayer capacitor plant.

II. PRESENTATIONS AT THE JOINT SEMINAR

M-20 Sakabe, Takagi, and Wakino Murata

This was an update of the work presented at the 1982 Joint Seminar about a dielectric having the general formula $(Ba_{1-x}^{Ca} Ca_{x}^{O})_{m} (Ti_{1-y}^{Cr} Cr_{y}^{O})$. The materials retained a high resistivity when fired in a reducing atmosphere compatible with Ni electrodes if x > 0 and m > 1. My suggestion at that time, that some Ca was then forced onto octahedral sites where it serves as an acceptor impurity, $Ca_{Ti}^{"}$, is now generally accepted.

Murata has been manufacturing these BME multilayers for 3 years and is now producing 20 million per month. They expect this rate to

increase substantially and are constructing a new building for this purpose (see Section III).

This start-up and rate of production is very modest compared with the predictions heard in 1982. The delay seems to have been caused by problems with the high temperature leakage current, and that has now been solved by the addition of a low temperature anneal after sintering. This application of basic defect chemistry reduces the oxygen-excess, p-type conduction caused by the high acceptor dopant concentration. This has now opened the way to a large market in the 0.1-100 μ f range. It is only at 0.1 μ f and above that the cost-saving in electrode metal is sufficient to justify the additional production costs of the BME process.

M-19 Kishi, Wada, Murai, Chazono, and Yamaoka Taiyo Yuden

Taiyo Yuden is now producing 5 million/month of their own version of a BME multilayer. Their composition is described as $(Ba_{1-x-y}Sr_xCa_y)$ $(Ti_{1-z}Zr_z)0_3$, and an alkaline earth lithium silicate glass is added as a sintering aid. Contrary to the Murata approach, there is no attempt to make the ceramic composition rich in alkaline earths. Yamoaka indicated, however, that the Ca content is necessary, and the glass must contain alkaline earths. The result, I believe, is that the ceramic takes up additional alkaline earths from the glass phase, making it alkaline earth rich, and forcing some of the Ca onto the Ti-sites. Thus in a rather indirect way, a composition very similar to the Murata dielectric is achieved. The low firing temperature (1100-1200°C) makes it unnecessary to give these units a separate anneal to reduce the hot leakage.

M-21 Fujikawa, Yokoe, and Hamano Kyocera

Kyocera described their own version of a dielectric for BME multilayers and are apparently producing a few million/month. Their major dopants are MnO and Y_2O_3 . The MnO serves as a conventional acceptor dopant while Y_2O_3 helps to flatten the TC curve. The use of

 Y_2O_3 is a little tricky, as we have shown that Y can act as a Ba-site donor, Y_{Ba}^{\bullet} , in the presence of excess TiO_2 . That would tend to cancel out the acceptor effect of the MnO and could even lead to semiconduction, but it appears that their compositions contain more Mn that Y, so that there is still a net acceptor excess no matter where the Y resides.

W-21 Shirasaki and Haneda NIRIM and TDK

This poster summarized Dr. Shirasoki's personal explanation of semiconduction in donor-doped BaTiO₃. This has been published before and is based on his assertion that the generally accepted model cannot explain some observed phenomena. The usual model is that the donor impurity substitutes for one of the host cations, depending on its size, and gives a positively charged impurity center that is compensated by free electrons

$$La_{2}O_{3} + 2TiO_{2} \longrightarrow 2La_{Ba}^{\bullet} + 2Ti_{Ti} + 6O_{0} + \frac{1}{2}O_{2} + 2e'$$
 (1)

$$2BaO + Nb_2O_5 \longrightarrow 2Ba_{Ba} + 2Nb_{Ti}^{\bullet} + 6O_0 + \frac{1}{2}O_2 + 2e'$$
 (2)

This is in agreement with a wide variety of experimental evidence. Dr. Shirasaki proposes that the donor centers are compensated by cation vacancies and that because this "loosens the lattice", a corresponding amount of oxygen is also lost leaving oxygen vacancies and electrons:

$$La_{2}O_{3} + 3TiO_{2} \longrightarrow 2La_{Ba}^{\bullet} + V_{Ba}^{"} + 3Ti_{Ti} + 8O_{o} + \frac{1}{2}O_{2} + V_{o}^{"} + 2e'$$
 (3)

Available thermodynamic evidence does not confirm the "loosening of the lattice", and it is very unlikely that the system would choose to form so many more defects than necessary. Purported difficulties with the usual model can be traced to misinterpretations of published results. I believe that the proposed model is clearly incorrect.

III. PLANT AND LABORATORY VISITS

Murata: Tour of MLC Plant in Takefu

The capacitor division of Murata is known as the Fukui Murata Manufacturing Co., Ltd., and is located primarily in Fukui Prefecture near the Japan Sea north of Kyoto. Four major plants in that area produce ceramic capacitors of various types:

Takefu: monolithic chips, 1400 employees

Miyasaki: monolithic epoxy coated radial axial and molded types

(a "new" plant), 450 employees

Ozawara: feed through and wedge shapes, 100 employees

Shirayama: barrier layer, 230 employees

The Takefu plant produces 1.2 billion MLCs/month(!), mostly chips. They also produce 0.4 billion very small chips/month in a new plant in Izumo, further west along the coast. This plant is described as having twice the area of the Takefu plant. They also manufacture 0.4 billion MLCs/month in Singapore, and 0.6 billion discs/month at Yokaichi near Kyoto. The engineering staff in the three main Fukui plants totals 620, almost all college graduates. This includes a substantial number who design almost all of their product equipment.

Capacitor sales by Murata totaled \$322,000,000 in 1985, an increase of 40% over the previous year (!). This is 38% of total Murata sales. 39% of their total sales are outside of Japan; 17% go to North and South America. Murata claims to have 50% of the world market in MLCs.

On November 13, we toured the main MLC plant in Takefu. This is a very well maintained complex of about eight buildings. We were given a complete and open tour of all phases of the production process. Up to the firing step, everything was done under Class 10,000 clean room conditions. We could not enter these areas, but there were sufficient windows to give a good view.

There was nothing particularly remarkable about their production process; the procedures were quite traditional. It was all done, however, in a very neat and well-organized environment, and, of course,

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on an enormous scale. As indicated earlier, they design and build most of their production equipment. I was particularly impressed by their test facility, where chips were being automatically loaded into each test stand at the rate of 5/second. Each chip is tested for capacitance, dissapation factor, leakage current at two voltage levels, and subjected to a flash voltage. They had 100 test stands giving a total capacity of 1.8 million chips/hour.

The BME units are fired in N_2 - N_2 atmospheres with the oxygen activity being measured with zirconia sensors. They are constructing a new building that will be devoted to BME production. It appears that they will be producing about 100 million/month within 2-3 years. It is obvious that Murata is very serious about the BME market. They see these units in the higher capacitance range as low-cost replacements for solid tantalum capacitors.

BME capacitors are also produced by Murata-Erie in the U.S. Interestingly enough, they use a totally different composition that is not initially acceptor-doped. They fire near the Ni-NiO equilibrium condition with the result that some Ni is oxidized and dissolved into the ceramic where it becomes the acceptor dopant.

Murata feels that the more highly conducting Cu would be necessary only in high frequency NPO units. They are working on a $(Mg-Ca)TiO_3$ composition with a k of 20, but it is not yet in production.

They profess to have no reliability problems with the BME units, and expect that they will soon be able to guarantee a failure rate below 10 ppm/1000 hours. At that point customers will not need to use an incoming inspection test.

On November 14, we visited the Murata Research Laboratory at Nagaokakyo-shi, near Kyoto. Once again we had a very open tour and saw a very well-equipped laboratory. I was asked to give a presentation of the material included in my poster from the Joint Seminar.

My hosts for the Murata visit were Dr. K. Wakino and Mr. Y. Sakabe.

NEC: Visit to Research Laboratory

On November 17 we visited the Central Research Laboratories of NEC in Kawasaki City. The hosts were Drs. M. Yonezawa and T. Ohno. About

five months ago, a Materials Development Center under the direction of Dr. Ohno was formed separately from the Fundamental Research Laboratory. Dr. Yonezawa heads the Materials Research Laboratory in the latter organization. The organization and topics covered are summarized as follows:

A. Fundamental Research Laboratories

1. Exploratory

III-V compounds, molecular beam epitaxy Bioelectronics Ultrafine structures, focused ion beams Computational physics and chemistry Radiation sensitive organic materials

2. Semiconductor Research Laboratory

Si crystals

III-V crystals

Material and device process evaluation

- 3. Materials Research Laboratory (M. Yonezawa)
 - a. Electronic ceramics
 - i. Low firing X7R MLC composition

Pb($Mg_{1/2}W_{1/2}$)O₃-PbTiO₃-PbZrO₃, modified with about 2 mol % Pb($Mm_{1/3}$ Nb_{2/3}O₃)

to meet X7R

k = 2300

DF = 0.9%

IR = 3800 Megohm μ F (25°)

1000 (125°)

Firing temp. 980°

No failures with 50 volts on 18 µm layers at 145°

Now moved to production (80 million/month)

ii. Ultrafine powders

RF plasma CVD

Nitrides (AlN), carbides, oxides

iii. New functional thin films

High thermal conductivity

diamond

amorphous carbon

Ferroelectric thin films

BaTiO₃

 $Ba(Ti_{1-x}Zr_x)0_3$

PbT103

PLZT

iv. Metals

Rapid quench

(Ta-W)-Si-B, Nb₃Ge high crystallization temperatures for ICs, to survive processing

without crystallization

Artificial superstructure

Mo/Ni, Co/Cr, metal/insulation

B. Materials Development Laboratory (Ohno)

1st Development Department (Takahashi)

1. Optoelectronics

Laser hosts

Nd-YAG

Gd₃Sc₂Ga₃O₁₂:Nd,Cr

2. Piezoelectric devices

Sonar (broad band) for Mn modules

Multilayer actuator for ink jet printer head -

will be on the market soon

Ceramic filter for 1.544 Mhz. communication system

 $\mathrm{Sr_2^{Nb}_2^{0}_7}$ and $\mathrm{Sr_2^{Ta}_2^{0}_7}$ single crystals. (This was of interest to me because we are studying the defect chemistry of these materials.)

2nd Development Department (Takamizawa)

1. Low firing multilayer substrates for high speed computers

Pb borosilicate glass: Al₂O₃ 45:55 weight %

Firing temp. 900°

k = 7.5

DF = 0.37

 $\rho = 3 \times 10^{14} \Omega cm$

Strength 3000 kg/cm² (\sim A1₂0₃)

Thermal cond. 0.01 cal/deg cm sec (< Al₂0₃ but OK

for high speed computers)

Metallization: Au, Ag-Pd, Ag

2. Monolithic multicomponent ceramic substrate

Insulator - same as above

Dielectric: $Pb(Fe_{2/3}w_{1/3})O_3 \cdot Pb(Fe_{1/2}Nb_{1/2})O_3$

k = 7000

Resistor: RuO,

Important to match the shrinkage, especially of

insulator and dielectric

Capacitance and resistance as an integral part of the substrate

3. AlN

Multilayer structures with 3 metallized layers

- C. Optoelectronic Research Laboratories
 - 1. Basic OE Research

crystal growth and processing, quantum effect optical devices

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2. OE Device Research Laboratory

optical single-crystal devices for communication and information processing

3. OE Equipment Research Laboratory

systems research lab

optical communication and switching

gas lasers

4. Display Device Research Lab

National Institute for Research in Inorganic Materials (NIRIM)

NIRIM was the first organization to be located in Tsukuba Science

City (1972), where 46 national laboratories and universities are

currently located, about 40 miles northeast of Tokyo. It is a major national laboratory, devoted mostly to research on ceramic materials. They work closely with industries, including a system for Visiting Research Officers, and their main goal is to transfer technology from the laboratory to an industry. NIRIM is one of six national research laboratories "attached" to the Science and Technology Agency that reports directly to the Office of the Prime Minister. A number of other laboratories are part of the Agency of Industrial Science and Technology, part of MITI (Ministry of International Trade & Industry).

NIRIM operates on a "group system". Groups are formed to attack a specific problem, usually for a period of five years. The project is then reviewed and either terminated or extended for a fixed period. Thus the staff is in a constant state of flux as groups are started up and terminated. The distribution of groups in 1986 is indicated on the following page.

My host was Dr. S. Shirasaki and we quickly agreed not to discuss the defect chemistry of perovskites because "we have a difference" (see the earlier discussion of paper W-21). Instead, I had technical discussions with four groups:

1. ZnO varistor. It was observed that ZnO doped with Li_20 is an insulator, while when doped with Al_20_3 it is a semiconductor. This is exactly what is expected for a reduction-type semiconductor; Al is a donor impurity $\operatorname{Al}_{2n}^{\bullet}$ compensated by electrons. Once again, however, the semiconduction is attributed to a combination of oxygen vacancies and electrons. Actually the concentration of oxygen vacancies will be suppressed by donor impurities, since they are both positively charged.

2. Effect of impurities on the anatase-rutile transition in TiO₂.

Dy, among others, was found to affect the transition temperature, and this was attributed to its presence as an interstitial donor $\mathrm{Dy}_{T}^{\bullet}$. I would expect it to be a substitutional acceptor, $\mathrm{Dy}_{Ti}^{\bullet}$, since that is a less highly charged defect.

3. Easily sintered perovskite. This was reported to be in use by 50 companies. The concept seems to be to accomplish a two-phase precipitation. For PZT, for example, a solution of Pb + Zr is precipipated with NH $_3$ to give PZ with residual Pb in solution. TiCl $_4$ is then added to precipitate PT. The mixture is calcined at 700-900° to give a particle size of 0.02 µm. When made in this way, PLZT can be sintered in air to transparency, and Ba(Zn $_1/3$ Nb $_1/3$)0 $_3$ can be sintered at 1200° with near theoretical density being achieved at 1400°.

It is not clear to me how or why this works.

4. Electron microscopy. NIRIM has a very well equipped laboratory with very competent staff (Drs. Bando and Horiuchi). They have had a 1.25 MeV microscope for about 10 years. It has a resolving power of 1.6 A, and has been heavily used to obtain some excellent lattice images for a variety of materials. It is interesting to note that a 400 keV microscope that they have had for about 3 years (JEM-4000EX) gives equivalent results. We will be receiving a similar instrument (Phillips 430) at Lehigh in about four months.

Sumitomo Metal Mining - Ichikawa

My final visit was on November 19 to the Central Research Laboratories of Sumitomo Metal Mining Co. My host was Mr. Ko Takada, who had just returned after spending nearly two years in our laboratory. This is a very well equipped laboratory working on a variety of ceramics-related projects.

Mr. Nishii described the activities of the Applied Chemistry Team that is working on powder preparation and applications. They are investigating ceramics ($\mathrm{Si}_3\mathrm{N}_4$, PSZ, ZrO_2), electronic ceramics (PZT Ba-ferrite), monodispersed spherical powders (TiO_2 , ZrO_2 , PSZ, SiO_2 , $\mathrm{Ta}_2\mathrm{O}_5$, $\mathrm{Nb}_2\mathrm{O}_5$ 0.2-0.7 µm), and ultrafine powders (Ta, W, Nb, $\mathrm{Si}_3\mathrm{N}_4$, BN, borides, carbides). They use wet processes:

controlled precipitation and sol-gel, including multistage precipitation (see visit to NIRIM) hydrolysis of alkoxides

hydrothermal, hybrid DC + RC plasma.

Mr. Nomura described his work on microwave ceramics. With the addition of 1% Mn, they can sinter $Ba(Mn_{1/3}Ta_{2/3})0_3$ to 98.47% of theoretical density. This gives a Q of 16,800 and k of 25 at 10.5 Ghz with a temperature coefficient of 3 ppm/°C. Dr. Matsumoto and Mr. Hiuga described a rapid sintering process for BMT without addition of impurities. They lower the sample into the furnace at 1650° for 5 min. This gives a cubic structure without pyrochlore phase, although a small amount of $Ba_5Ta_40_{15}$ is sometimes detected. An anneal in 0_2 for 100 hours at 1450°C gives an ordered structure. Q goes up with density and ordering. They make about 100 units/month for special, high-priced applications, such as satellites.



December 29, 1986

Dr. Stephen W. Freiman National Bureau of Standards Gaithersburg, MD 20899

Dear Steve:

Enclosed is my trip report for the Third U.S.-Japan Seminar on Dielectric and Piezoelectric Materials. It was a long trip for me but I feel it was worthwhile.

Sincerely,

Robert W. Vest Turner Professor of

Engineering

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Enclosure



TRIP REPORT - Robert W. Vest

Third U.S.: Japan Seminar on Dielectric and Piezoelectric Ceramics. November 9-12, 1986, Toyama, Japan

Summary and Recommendations

My overall impression was very favorable and I think this seminar should be continued. The primary benefits to the U.S. are in the contacts established between individual scientists, which will lead to closer liaison in the future; the technical aspects alone would not justify the expense involved. The hospitality shown the American attendees was outstanding, and we should try very hard to reciprocate in 1988.

The format of 4 minute presentations followed by the poster sessions worked reasonably well and I cannot think of a better way to handle that many papers. Certainly, there should not be parallel sessions. The conference organizers should try harder to get accurate information to the authors on the size of the posters; there was much more space available than we had been told. The program chairmen should also try harder to only solicit papers covering research done during the previous 2 years. For example, Banno's paper was essentially the same one he presented at Williamsburg in 1984. Some changes should be made if roundtable discussions are to be kept as part of the format. The one on Processing turned out to be a semi-circular table; it was only the American half that said anything. Perhaps it would help if one representative from each country prepared a short list of topics which he knows scientists from his country will address in order to get the discussion started.

We should seriously consider organizing a Satellite Symposium for scientists and managers from U.S. industry to follow the 1988 Seminar. If

done right, this could also get more representatives from U.S. industry to participate in the Seminar. The format of the Symposium in Tokyo on November 14, 1986 was good and should be followed, and we should treat the Japanese lecturers at least as well as the four Americans were treated this fall.

Technical Aspects

The majority of the materials and processing papers had been previously presented in more depth at other conferences, and so I saw very little that was new. Perhaps I attend too many conferences. I did get excited about some of the applications papers by the Japanese, particularly the session on actuators. Several of these contained ideas that were new to me; the monomorph structure discussed by the researchers at Sophia University and Toyo Soda (W-12 and W-15) was very intriguing. I was also struck by the absence of any U.S. papers in the actuator session, but I suppose this is a reflection of the lack of participation by U.S. industrial laboratories.

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